PATENT ASSIGNMENT COVER SHEET

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| SUBMISSION TYPE: | NEW ASSIGNMENT |
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| NATURE OF CONVEYANCE: | RELEASE OF SECURITY INTEREST |

CONVEYING PARTY DATA

| Name | Execution Date |
|--------------------------------------|----------------|
| CORTLAND CAPITAL MARKET SERVICES LLC | 04/01/2022 |

RECEIVING PARTY DATA

| Name: | HILCO PATENT ACQUISITION 56, LLC | |
|-----------------|----------------------------------|--|
| Street Address: | 401 N. MICHIGAN AVE., SUITE 1630 | |
| City: | CHICAGO | |
| State/Country: | ILLINOIS | |
| Postal Code: | 60611 | |
| Name: | BELL SEMICONDUCTOR, LLC | |
| Street Address: | 401 N. MICHIGAN AVE., SUITE 1630 | |
| City: | CHICAGO | |
| State/Country: | ILLINOIS | |
| Postal Code: | 60611 | |
| Name: | BELL NORTHERN RESEARCH, LLC | |
| Street Address: | 401 N. MICHIGAN AVE., SUITE 1630 | |
| City: | CHICAGO | |
| State/Country: | ILLINOIS | |
| Postal Code: | 60611 | |

PROPERTY NUMBERS Total: 978

| Property Type | Number |
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| Patent Number: | 6651202 |
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| Patent Number: | 6289298 |
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| Application Number: | 14053194 |
| Application Number: | 14093189 |
| Application Number: | 11364142 |
| Application Number: | 13658336 |
| Application Number: | 14305794 |

CORRESPONDENCE DATA

Fax Number:

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 5749031499

Email: jgammon@hilcoglobal.com

Correspondent Name: JOSHUA GAMMON
Address Line 1: 401 N. MICHIGAN AVE.

Address Line 2: SUITE 1630

Address Line 4: CHICAGO, ILLINOIS 60611

| NAME OF SUBMITTER: | JOSHUA GAMMON |
|--------------------|--|
| SIGNATURE: | //Joshua Gammon// |
| DATE SIGNED: | 04/15/2022 |
| | This document serves as an Oath/Declaration (37 CFR 1.63). |

Total Attachments: 215

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RELEASE OF PATENT SECURITY INTEREST

This RELEASE OF PATENT SECURITY INTEREST ("Release") is made and effective as of April 1, 2022 and granted by CORTLAND CAPITAL MARKET SERVICES LLC (the "Collateral Agent"), as collateral agent (in such capacity, together with its successors and permitted assigns) for the secured parties under the Loan Agreement referred to below (the "Secured Parties"), in favor of HILCO PATENT ACQUISITION 56, LLC, a Delaware limited liability company, BELL SEMICONDUCTOR, LLC, a Delaware limited liability company (each a "Grantor" and collectively the "Grantors") and their successors, assigns and legal representatives.

Background

Pursuant to the Term Loan Agreement dated as of January 24, 2018 as amended on November 17, 2020 (the "Loan Agreement") among Hilco Patent Acquisition 56, LLC, as borrower, Bell Semiconductor, LLC and Bell Northern Research, LLC, as guarantors, the Collateral Agent and the lenders party thereto, the Grantors executed and delivered to the Collateral Agent (i) that certain Security Agreement by and among the Grantors and the Collateral Agent dated as of January 24, 2018 (the "Master Security Agreement") and (ii) that certain Patent Security Agreement by and among the Grantors and the Collateral Agent dated as of January 24, 2018 (the "Patent Security Agreement" and, together with the Master Security Agreement, the "Security Agreements");

Pursuant to the Security Agreements, each Grantor pledged and granted to the Collateral Agent for the ratable benefit of the Secured Parties a security interest in and to all of the right, title and interest of such Grantor in, to and under the Patent Collateral (as defined below);

The Patent Security Agreement was recorded with the United States Patent and Trademark Office at Reel 045216, Frame 0020 on February 1, 2018; and

The Grantors have requested that the Collateral Agent enter into this Release in order to effectuate, evidence and record the release and reassignment to the Grantors of any and all right, title and interest the Collateral Agent and the Secured Parties may have in the Patent Collateral pursuant to the Security Agreements.

Collateral Agent therefore agrees as follows:

- 1. Release of Security Interest. Collateral Agent, on behalf of itself and the Secured Parties, their successors, legal representatives and assigns, hereby terminates the Patent Security Agreement and terminates, releases and discharges any and all security interests that it has pursuant to the Security Agreements in any and all right, title and interest of the Grantors, and reassigns to the Grantors any and all right, title and interest that it may have, in, to and under the following (collectively, the "Patent Collateral"):
 - (a) any and all patents, patent applications and other patent rights and any other governmental authority-issued indicia of invention ownership, including the patents and patent applications listed in Schedule 1 hereto, and all reissues, divisions, continuations, continuations-in-part, renewals, extensions and reexaminations thereof and amendments thereto (the "Patents");

- (b) all rights of any kind whatsoever of such Grantor accruing under any of the foregoing provided by applicable law of any jurisdiction, by international treaties and conventions and otherwise throughout the world;
- (c) any and all license and other agreements in which such Grantor has granted or is granted a license or other right under any Patent;
- (d) any and all royalties, fees, income, payments and other proceeds now or hereafter due or payable with respect to any and all of the foregoing; and
- (e) any and all claims and causes of action, with respect to any of the foregoing, whether occurring before, on or after the date hereof, including all rights to and claims for damages, restitution and injunctive and other legal and equitable relief for past, present and future infringement, misappropriation, violation, misuse, breach or default, with the right but no obligation to sue for such legal and equitable relief and to collect, or otherwise recover, any such damages.
- 2. <u>Further Assurances</u>. Collateral Agent agrees to take all further actions, and provide to the Grantors and their successors, assigns and legal representatives all such cooperation and assistance, including, without limitation, the execution and delivery of any and all further documents or other instruments, as the Grantors and their successors, assigns and legal representatives may reasonably request in order to confirm, effectuate or record this Release.
- 3. <u>Governing Law</u>. This Release and any claim, controversy, dispute or cause of action (whether in contract or tort or otherwise) based upon, arising out of or relating to this Release and the transactions contemplated hereby shall be governed by, and construed in accordance with, the laws of the United States and the State of New York, without giving effect to any choice or conflict of law provision or rule (whether of the State of New York or any other jurisdiction).

[SIGNATURE PAGE FOLLOWS]

Collateral Agent has caused this Release to be duly executed and delivered by its officer duly authorized as of the date stated in the first paragraph above.

CORTLAND CAPITAL MARKET SERVICES LLC,

as Collateral Agent

sy: garage

Name: Emily Ergang Pappas

Title: Head of Legal, North America

ACKNOWLEDGED AND AGREED as of the date stated in the first paragraph above:

HILCO PATENT ACQUISITION 56, LLC, as Grantor

By: _____

Name: Michael Friedman

Title: CEO

BELL SEMICONDUCTOR, LLC, as Grantor

Name John Veschi

Titlk CEO

BELL NORTHERN RESEARCH, LLC, as Grantor

 $\mathbf{R}_{\mathbf{W}}$

Name: Afzal Dean

Title: CEO

SCHEDULE 1 TO RELEASE OF PATENT SECURITY INTEREST [SEE ATTACHED.]

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | THE CONTRACTOR OF THE CONTRACT |
|----------|----------|------------|------------|-----------|--------------------------|--|
| 08939689 | 5888120 | 1997-09-29 | 1999-03-30 | Expired | United States of America | Method and apparatus for chemical mechanical polishing |
| 09216395 | | 1998-12-18 | | Abandoned | United States of America | Method and Apparatus for Chemical Mechanical Polishing |
| 08700650 | | 1996-08-14 | | Abandoned | United States of America | Off-Axis Illuminator Lens Mask For Photolithographic Projection System |
| 09105546 | 5973767 | 1998-06-26 | 1999-10-26 | Expired | United States of America | Off-axis illuminator lens mask for photolithographic projection system |
| 09089461 | 6130428 | 1998-06-02 | 2000-10-10 | Granted | United States of America | Laser fault correction of semiconductor devices |
| 09604865 | 6407559 | 2000-06-28 | 2002-06-18 | Granted | United States of America | Laser fault correction of semiconductor devices |
| 08955384 | 5897381 | 1997-10-21 | 1999-04-27 | Expired | United States of America | Method of forming a layer and semiconductor substrate |
| 08954791 | 5893952 | 1997-10-21 | 1999-04-13 | Expired | United States of America | Apparatus for rapid thermal processing of a wafer |
| 08678718 | 5756369 | 1996-07-11 | 1998-05-26 | Expired | United States of America | Rapid thermal processing using a narrowband infrared source and feedback |
| 08924902 | 5926720 | 1997-09-08 | 1999-07-20 | Expired | United States of America | Consistent alignment mark profiles on semiconductor wafers using PVD shadowing |
| 09198208 | 6239499 | 1998-11-23 | 2001-05-29 | Expired | United States of America | Consistent alignment mark profiles on semiconductor wafers using PVD shadowing |
| 09363084 | | 1999-07-28 | | Abandoned | United States of America | Nitrogen Implanted Polysilicon Gate For Mosfet Gate Oxide Hardening |
| 08957692 | 6017808 | 1997-10-24 | 2000-01-25 | Expired | United States of America | Nitrogen implanted polysilicon gate for MOSFET gate oxide hardening |
| 09022588 | 6117795 | 1998-02-12 | 2000-09-12 | Granted | United States of America | Use of corrosion inhibiting compounds in post-etch cleaning processes of an integrated circuit |
| 09583297 | | 2000-05-30 | | Abandoned | United States of America | Use Of Corrosion Inhibiting Compounds In Post-Etch Cleaning Processes Of An Integrated Circuit |
| 09081403 | 6239491 | 1998-05-18 | 2001-05-29 | Granted | United States of America | Integrated circuit structure with thin dielectric between at least local interconnect level and first metal interconnect level, and process for making same |
| 09790821 | 6486056 | 2001-02-22 | 2002-11-26 | Granted | United States of America | Process for making integrated circuit structure with thin dielectric between at least local interconnect level |
| 08374193 | 5646073 | 1995-01-18 | 1997-07-08 | Expired | United States of America | Process for selective deposition of polysilicon over single crystal silicon substrate and resulting product |
| 08823829 | 5818100 | 1997-03-25 | 1998-10-06 | Expired | United States of America | Product resulting from selective deposition of polysilicon over single crystal silicon substrate |
| 08566161 | | 1995-11-30 | | Abandoned | United States of America | Product Resulting From Selective Deposition Of Polysilicon Over Single Crystal Silicon Substrate |
| 08879100 | 6121159 | 1997-06-19 | 2000-09-19 | Expired | United States of America | Polymeric dielectric layers having low dielectric constants and improved adhesion to metal lines |

| 00618311 | | | | | | Polymeric dielectric layers having low dielectric constants and improyed |
|----------|---------|------------|------------|-----------|--------------------------|---|
| TTZOTOGO | 6455934 | 2000-07-10 | 2002-09-24 | Expired | United States of America | adhesion to metal lines |
| 09362648 | 6273798 | 1999-07-27 | 2001-08-14 | Expired | United States of America | Pre-conditioning polishing pads for chemical-mechanical polishing |
| 08841947 | 5990010 | 1997-04-08 | 1999-11-23 | Expired | United States of America | Pre-conditioning polishing pads for chemical-mechanical polishing |
| 08791244 | 6117736 | 1997-01-30 | 2000-09-12 | Expired | United States of America | Method of fabricating insulated-gate field-effect transistors having different gate capacitances |
| 09594478 | 6300663 | 2000-06-15 | 2001-10-09 | Expired | United States of America | Insulated-gate field-effect transistors having different gate capacitances |
| 08701476 | 5905381 | 1996-08-22 | 1999-05-18 | Expired | United States of America | Functional OBIC analysis |
| 09244327 | 6154039 | 1999-02-03 | 2000-11-28 | Expired | United States of America | Functional OBIC analysis |
| 09109331 | 6071818 | 1998-06-30 | 2000-06-06 | Granted | United States of America | Endpoint detection method and apparatus which utilize an endpoint polishing layer of catalyst material |
| 09534652 | 6258205 | 2000-03-24 | 2001-07-10 | Granted | United States of America | Endpoint detection method and apparatus which utilize an endpoint polishing layer of catalyst material |
| 08684022 | 5728612 | 1996-07-19 | 1998-03-17 | Expired | United States of America | Method for forming minimum area structures for sub-micron CMOS ESD protection in integrated circuit structures without extra implant and mask steps, and articles formed thereby |
| 08748372 | 5843813 | 1996-11-13 | 1998-12-01 | Expired | United States of America | I/O driver design for simultaneous switching noise minimization and ESD performance enhancement |
| 08936829 | 5970321 | 1997-09-25 | 1999-10-19 | Expired | United States of America | Method of fabricating a microelectronic package having polymer ESD protection |
| 08595021 | 5869869 | 1996-01-31 | 1999-02-09 | Expired | United States of America | Microelectronic device with thin film electrostatic discharge protection structure |
| 08723140 | 5955762 | 1996-10-01 | 1999-09-21 | Expired | United States of America | Microelectronic package with polymer ESD protection |
| 09188929 | | 1998-11-09 | | Abandoned | United States of America | Formation Of Gradient Doped Profile Region Between Channel Region And Heavily Doped Source/Drain Contact Region Of MOS Device In Integrated Circuit Structure Using A Re-Entrant Gate Electrode And A Higher Dose Drain Implantation |
| 08690592 | 5877530 | 1996-07-31 | 1999-03-02 | Expired | United States of America | Formation of gradient doped profile region between channel region and heavily doped source/drain contact region of MOS device in integrated circuit structure using a re-entrant gate electrode and a higher dose drain implantation |
| 08552461 | 5670425 | 1995-11-09 | 1997-09-23 | Expired | United States of America | Process for making integrated circuit structure comprising local area interconnects formed over semiconductor substrate by selective deposition on seed layer in patterned trench |
| 08873809 | 5895261 | 1997-06-12 | 1999-04-20 | Expired | United States of America | Process for making integrated circuit structure comprising local area interconnects formed over semiconductor substrate by selective deposition on seed layer in patterned trench |

| Impact of F Species on Plasma Charge Damage in a RF Aher | United States of America | Abandoned | | 1900-01-01 | | 60384499 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| Method of reducing process plasma damage using optical spectroscopy | United States of America | Granted | 2004-01-06 | 2002-07-12 | 6673200 | 10195775 |
| Method of preventing resist poisoning in dual damascene structures | United States of America | Granted | 2004-03-30 | 2001-12-19 | 6713386 | 10025304 |
| Method of preventing resist poisoning in dual damascene structures | United States of America | Granted | 2005-11-29 | 2003-12-31 | 6969683 | 10750348 |
| Process independent alignment marks | United States of America | Granted | 2005-02-15 | 2001-06-22 | 6856029 | 09887131 |
| Process independent alignment marks | United States of America | Lapsed | 2006-08-22 | 2004-12-01 | 7095483 | 11000772 |
| Maskless Vortex Phase Shift Optical Direct Write Lithography | United States of America | Lapsed | 2011-11-15 | 2004-12-14 | 8057963 | 11011896 |
| Maskless Vortex Phase Shift Optical Direct Write Lithography | United States of America | Lapsed | 2013-02-19 | 2011-10-05 | 8377633 | 13253554 |
| Maskless Vortex Phase Shift Optical Direct Write Lithography | United States of America | Lapsed | 2015-11-17 | 2012-12-20 | 9188848 | 13722648 |
| Vortex Phase Shift Mask Applied to Optical Direct Write | United States of America | Abandoned | | 2004-06-10 | | 60578890 |
| capacitance | United States of America | Granted | 2005-03-15 | 2002-12-19 | 6867127 | 10327283 |
| Diamond metal-filled natterns achieving low parasitic coupling | | מומוונכמ | 41-70-0007 | 01-71-4007 | 0770710 | 11010100 |
| Diamond metal-filled patterns achieving low parasitic coupling capacitance | United States of America | | 2006-02-17 | 2004-12-16 | 6000716 | 11016/69 |
| Adjustable transmission phase shift mask | United States of America | Lapsed | 2005-01-11 | 2001-11-09 | 6841308 | 10039508 |
| Adjustable transmission phase shift mask | United States of America | Lapsed | 2006-06-27 | 2004-10-25 | 7067223 | 10972898 |
| Adjustable Transmission Phase Shift Mask | United States of America | Abandoned | | 2006-05-03 | | 11381409 |
| Systems and Methods For Wafer Polishing | United States of America | Abandoned | | 2005-06-21 | | 11158450 |
| Systems and methods for wafer polishing | United States of America | Granted | 2007-04-10 | 2005-02-22 | 7201633 | 11063384 |
| lon recoil implantation and enhanced carrier mobility in CMOS device | United States of America | Lapsed | 2006-10-31 | 2005-04-04 | 7129516 | 11098290 |
| lon recoil implantation and enhanced carrier mobility in CMOS device | United States of America | Lapsed | 2006-01-03 | 2003-04-18 | 6982229 | 10418375 |
| EFFICIENT POWER MANAGEMENT METHOD IN INTEGRATED CIRCUIT THROUGH A NANOTUBE STRUCTURE | United States of America | Granted | 2011-09-13 | 2010-10-27 | 8017512 | 12912791 |
| CONFIGURABLE POWER SEGMENTATION USING A NANOTUBE STRUCTURE | United States of America | Granted | 2010-12-07 | 2005-11-23 | 7847285 | 11286558 |
| Method for protecting a semiconductor device with a superconductive line | United States of America | Expired | 1997-07-01 | 1995-05-30 | 5644143 | 08454542 |
| Techniques for forming superconductive lines | United States of America | Expired | 1997-01-14 | 1994-04-22 | 5593918 | 08233607 |
| Use of reticle stitching to provide design flexibility | United States of America | Expired | 1997-07-29 | 1994-12-13 | 5652163 | 08357728 |
| Use Of Reticle Stitching To Provide Design Flexibility | United States of America | Abandoned | | 1997-07-29 | | 08902507 |
| Barrier metal technology for tungsten plug interconnection | United States of America | Expired | 1997-02-04 | 1995-01-24 | 5600182 | 08378027 |
| Method of making a barrier metal technology for tungsten plug interconnection | United States of America | Expired | 1998-10-27 | 1996-09-24 | 5827777 | 08718852 |
| Hitle | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|----------|----------|------------|------------|-----------|--------------------------|---|
| 10680503 | 6972840 | 2003-10-06 | တ | _ | United States of America | Method of reducing process plasma damage using optical spectroscopy |
| 10762788 | 7151059 | 2004-01-22 | 2006-12-19 | Granted | United States of America | MOS Transistor And Method Of Manufacture |
| 09597012 | 6740912 | 2000-06-20 | 2004-05-25 | Granted | United States of America | Semiconductor Device Free Of LDD Regions |
| 10291356 | | 2002-11-08 | | Abandoned | United States of America | High-K Dielectric Gate Material Uniquely Formed |
| 10643687 | 6919263 | 2003-08-19 | 2005-07-19 | Lapsed | United States of America | High-K dielectric gate material uniquely formed |
| 09408299 | 6323044 | 1999-09-29 | 2001-11-27 | Granted | United States of America | Integrated Circuit Capacitor And Associated Fabrication Methods |
| 09951178 | 8525358 | 2001-09-13 | 22-20-8002 | Granted | United States of America | Capacitor Having The Lower Electrode For Preventing Undesired Defects At The Surface Of The Metal Plug |
| 10459072 | 6806162 | 2003-06-11 | 2004-10-19 | Lapsed | United States of America | Method for composing a dielectric layer within an interconnect structure of a multilayer semiconductor device |
| | | | | | | Method for composing a dielectric layer within an interconnect structure |
| 09164069 | 6614097 | 1998-09-30 | 2003-09-02 | Lapsed | United States of America | of a multilayer semiconductor device |
| 12256677 | | 2008-10-23 | | Abandoned | United States of America | Method To Reduce Boron Penetration In SiGe Bipolar Device |
| 11694021 | 7456061 | 2007-03-30 | 2008-11-25 | Granted | United States of America | Method To Reduce Boron Penetration In SiGe Bipolar Device |
| 09886780 | 6649422 | 2001-06-21 | 2003-11-18 | Granted | United States of America | Integrated Circuit Having A Micromagnetic Device And Method Of Manufacture Therefor |
| 09338143 | 6255714 | 1999-06-22 | 2001-07-03 | Granted | United States of America | An Integrated Circuit Having A Micromagnetic Device And Method Of Manufacture Therefor |
| 10234354 | 7126198 | 2002-09-03 | 2006-10-24 | Lapsed | United States of America | Protruding Spacers For Self-Aligned Contacts |
| 11542864 | 7332775 | 2006-10-04 | 2008-02-19 | Granted | United States of America | Protruding Spacers For Self-Aligned Contacts |
| 09156719 | 6495407 | 1998-09-18 | 2002-12-17 | Granted | United States of America | Method Of Making An Article Comprising An Oxide Layer On A GaAs- Based Semiconductor Body |
| 09093557 | 5962883 | 1998-06-08 | 1999-10-05 | Expired | United States of America | Article Comprising An Oxide Layer On A GaAs-Based Semiconductor Body, And Method Of Making The Article |
| 11811519 | 7384801 | 2007-06-11 | 2008-06-10 | Granted | United States of America | Integrated circuit with inductor having horizontal magnetic flux lines |
| 10614307 | 7253497 | 2003-07-02 | 2007-08-07 | Granted | United States of America | Integrated circuit with inductor having horizontal magnetic flux lines |
| 09085913 | 5949112 | 1998-05-28 | 1999-09-07 | Granted | United States of America | Integrated Circuits with Tub-Ties |
| 09339306 | 6054342 | 1999-06-23 | 2000-04-25 | Granted | United States of America | Method Of Making Integrated Circuits With Tub-Ties |
| 08562235 | 5773338 | 1995-11-21 | 1998-06-30 | Expired | United States of America | Bipolar Transistor With MOS-Controlled Protection For Reverse-Biased Emitter-Base Junction |
| 09050711 | 5949128 | 1998-03-30 | 1999-09-07 | Expired | United States of America | Bipolar Transistor With MOS\(miControlled Protection For Reverse\\miBiased Emitter\(miBase Junction |
| 08347527 | 6445043 | 1994-11-30 | 2002-09-03 | Granted | United States of America | Process for Forming Isolation Regions in An Integrated Circuit and Structure Formed Thereby |
| 08620964 | 5763314 | 1996-03-22 | 1998-06-09 | | United States of America | Process For Forming Isolation Regions In An Integrated Circuit |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|----------|----------|------------|------------|---------|--------------------------|---|
| 08777008 | 5830619 | 1997-01-07 | 1998-11-03 | Expired | United States of America | Resist Materials |
| | | | | | | Processes Using Photosensitive Materials Including A Nitro Benzyl Ester |
| 08079310 | 6159665 | 1993-06-17 | 2000-12-12 | Granted | United States of America | Photoacid Generator |
| 10442533 | 6864152 | 2003-05-20 | 2005-03-08 | Granted | United States of America | Fabrication of trenches with multiple depths on the same substrate |
| 10931605 | 7189628 | 2004-08-31 | 2007-03-13 | Granted | United States of America | Fabrication of trenches with multiple depths on the same substrate |
| 09943403 | 6521520 | 2001-08-30 | 2003-02-18 | Granted | United States of America | Semiconductor wafer arrangement and method of processing a semiconductor wafer |
| 10321250 | 6707114 | 2002-12-16 | 2004-03-16 | Granted | United States of America | Semiconductor wafer arrangement of a semiconductor wafer |
| | | | | | | Semiconductor device with a pair of transistors having dual work function |
| 09162407 | 6211555 | 1998-09-29 | 2001-04-03 | Granted | United States of America | gate electrodes |
| | | | | | | Semiconductor device with a pair of transistors having dual work function |
| 09591108 | 6514824 | 2000-06-09 | 2003-02-04 | Granted | United States of America | gate electrodes |
| 09654689 | 6613651 | 2000-09-05 | 2003-09-02 | Lapsed | United States of America | Integrated circuit isolation system |
| 10383031 | 6831348 | 2003-03-06 | 2004-12-14 | Lapsed | United States of America | Integrated circuit isolation system |
| | 700,700 | 31.00.100. | 2000 | | Inited States of America | Apparatus and method to improve the resolution of photolithography |
| 10365056 | 0.20303 | 20 01 5005 | 2005 03 15 | | Inited States of America | Apparatus and method to improve the resolution of photolithography |
| 10702165 | 6830943 | 2003-11-04 | 2004-12-14 | Lapsed | United States of America | Thin film CMOS calibration standard having protective cover layer |
| 10194578 | 6674092 | 2002-07-12 | 2004-01-06 | Lapsed | United States of America | Thin film CMOS calibration standard having protective cover layer |
| 10164909 | 6555475 | 2002-06-07 | 2003-04-29 | Granted | United States of America | Arrangement and method for polishing a surface of a semiconductor wafer |
| 09750639 | 6439981 | 2000-12-28 | 2002-08-27 | Granted | United States of America | Arrangement and method for polishing a surface of a semiconductor wafer |
| 10607353 | 6831022 | 2003-06-26 | 2004-12-14 | Lapsed | United States of America | Method and apparatus for removing water vapor as a byproduct of chemical reaction in a wafer processing chamber |
| 10140536 | 6630411 | 2002-05-07 | 2003-10-07 | Granted | United States of America | Method and apparatus for removing water vapor as a byproduct of chemical reaction in a wafer processing chamber |
| 09960765 | 6504219 | 2001-09-21 | 2003-01-07 | Granted | United States of America | Indium field implant for punchthrough protection in semiconductor devices |
| 09469579 | 6342429 | 1999-12-22 | 2002-01-29 | Granted | United States of America | Method of fabricating an indium field implant for punchthrough protection in semiconductor devices |
| 10819253 | 7242056 | 2004-04-05 | 2007-07-10 | Granted | United States of America | Structure And Fabrication Method For Capacitors Integratible With Vertical Replacement Gate Transistors |
| 11809686 | 7633118 | 2007-05-31 | 2009-12-15 | Lapsed | United States of America | Structure And Fabrication Method For Capacitors Integratible With Vertical Replacement Gate Transistors |

| Integrated Circuit With Metal Cilicide Regions | United States of America | lanced | 2010-09-21 | 2007-06-22 | 7800226 | 11871306 |
|--|--------------------------|-----------|------------|------------|---------|----------|
| MOS Transistors With Improved Gate Dielectrics | United States of America | Lapsed | 2003-07-08 | 2000-03-07 | 6590241 | 09519909 |
| MOS Transistors With Improved Gate Dielectrics | United States of America | Granted | 2000-05-09 | 1998-05-28 | 6060406 | 09086252 |
| Method For Forming A High Quality Ultrathin Gate Oxide Layer | United States of America | Expired | 1999-08-17 | 1997-03-11 | 5940736 | 08814670 |
| System And Method For Forming A Thin Gate Oxide Layer | United States of America | Expired | 2001-06-12 | 1998-09-03 | 6246095 | 09146418 |
| Leakage | United States of America | Lapsed | 2006-07-25 | 2004-05-18 | 7081419 | 10847789 |
| Current Leakage | United States of America | Abandoned | | 2000-06-28 | | 09605931 |
| A Novel Gate Dielectric Structure For Reducing Boron Penetration And | | | | | | |
| Semiconductor Device Having A Doped Lattice Matching Layer And A Method Of Manufacture Therefor | United States of America | Granted | 2005-02-15 | 2004-03-31 | 6855991 | 10814680 |
| Semiconductor Device Having A Doped Lattice Matching Layer And A Method Of Manufacture Therefor | United States of America | Granted | 2004-05-18 | 2001-10-24 | 6737339 | 10003873 |
| Semiconductor Device Having A Doped Lattice Matching Layer And A Method Of Manufacture Therefor | United States of America | Abandoned | | 2004-03-31 | | 10814682 |
| Process For Fabricating A Semiconductor Device Having An Insulating Layer Formed Over A Semiconductor Substrate | United States of America | Granted | 2007-05-29 | 2004-06-24 | 7223677 | 10876183 |
| A Process For Fabricating A Semiconductor Device Having A GATE Dielectric Layer With A High Dielectric Constant | United States of America | Abandoned | | 2002-11-27 | | 10306565 |
| Stepped Etalon | United States of America | Granted | 2002-12-31 | 1999-05-14 | 6500521 | 09312386 |
| Stepped Etalon | United States of America | Lapsed | 2005-08-09 | 2001-08-21 | 6926841 | 09934283 |
| Device Comprising Micromagnetic Components For Power Applications And Process For Forming Device | United States of America | Granted | 2002-12-17 | 2000-04-19 | 6495019 | 09552627 |
| Micromagnetic Device Having Alloy Of Combalt, Phosphorus and Iron | United States of America | Granted | 2003-09-23 | 2001-12-20 | 6624498 | 10028594 |
| Ultra Thin Body Vertical Replacement Gate Mosfet | United States of America | Granted | 2003-10-21 | 2002-06-06 | 6635924 | 10164202 |
| Method Of Making Ultra Thin Body Vertical Replacement Gate Mosfet | United States of America | Granted | 2004-11-23 | 2003-08-27 | 6821851 | 10649140 |
| Device And Method For Protecting Electronic Component | United States of America | Granted | 2003-04-29 | 2000-05-30 | 6554137 | 09580522 |
| Device And Method For Protecting Electronic Component | United States of America | Granted | 2000-05-30 | 1999-02-05 | 6068130 | 09244857 |
| Barrier For Copper Metallization | United States of America | Granted | 2001-09-11 | 1998-12-22 | 6288449 | 09218649 |
| Barrier For Copper Metallization | United States of America | Granted | 2002-09-24 | 2000-11-28 | 6455418 | 09723557 |
| Structure And Fabrication Method For Capacitors Integratible With Vertical Replacement Gate Transistors | United States of America | Granted | 2011-03-22 | 2009-11-02 | 7911006 | 12610733 |
| An Integratible Vertical Replacement Gate (VRG)-type Poly-Nitride-Poly (PNP) Or Metal-Nitride-poly (MNP) Capacitor | United States of America | Abandoned | | 2001-09-18 | | 09956381 |
| Fabrication Method | United States of America | Granted | 2009-02-17 | 2007-06-01 | 7491610 | 11809873 |
| Method of Fabricating a Vertical Transistor and Capacitor | United States of America | Lapsed | 2010-04-20 | 2009-01-09 | 7700432 | 12319603 |
| | | | | | | |

| 08803703 | 08813732 | 09083168 | 09143037 | 09568265 | 09197833 | 08753859 | 10967900 | 10226930 | 09143274 | 09335707 | 09488662 | 10655050 | 11385156 | 08572196 | 08848141 | 08446122 | | 08468167 | 08150261 | 09911035 | 10978716 | 10675572 | 11827807 | 10245447 | AppNo |
|---|---|--|--|--|-----------------------------------|------------------------------------|---|--|--|--|--|--|--|---|--|--------------------------|--|--|---|---|---|---|---|--|-----------|
| 5843624 | 5879857 | 5998099 | 6297154 | 6380083 | 6110543 | 5976623 | 7015056 | 6869815 | 6027975 | 6197641 | 6638663 | 7053405 | 7282461 | 5625200 | 6054722 | 5653894 | | 5737496 | 5467883 | 6909150 | 7642188 | 7261745 | 7632690 | 7250356 | PatentNo |
| 1997-02-21 | 1997-03-07 | 1998-05-22 | 1998-08-28 | 2000-05-10 | 1998-11-23 | 1996-12-03 | 2004-10-18 | 2002-08-22 | 1998-08-28 | 1999-06-18 | 2000-01-20 | 2003-09-04 | 2006-03-21 | 1995-12-14 | 1997-04-28 | 1995-05-19 | | 1995-06-06 | 1993-11-27 | 2001-07-23 | 2004-11-01 | 2003-09-30 | 2007-07-13 | 2002-09-17 | FiledDate |
| 1998-12-01 | 1999-03-09 | 1999-12-07 | 2001-10-02 | 2002-04-30 | 2000-08-29 | 1999-11-02 | 2006-03-21 | 2005-03-22 | 2000-02-22 | 2001-03-06 | 2003-10-28 | 2006-05-30 | 2007-10-16 | 1997-04-29 | 2000-04-25 | 1997-08-05 | | 1998-04-07 | 1995-11-21 | 2005-06-21 | 2010-01-05 | 2007-08-28 | 2009-12-15 | 2007-07-31 | GrantDate |
| Expired | Expired | Expired | Granted | Granted | Expired | Expired | Lapsed | Granted | Granted | Granted | Granted | Lapsed | Granted | Expired | Expired | Expired | | Expired | Expired | Granted | Lapsed | Granted | Lapsed | Granted | Status |
| United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Country |
| Energy-Sensitive Resist Material And A Process For Device Fabrication Using An Energy-Sensitive Resist Material | Energy-Sensitive Resist Material And A Process For Device Fabrication Using An Energy-Sensitive Resist Material | Energy-Sensitive Resist Material And A Process For Device Fabrication UsingAn Energy-Sensitive Resist Material | Process For Semiconductor Device Fabrication Having Copper Interconnects | Process For Semiconductor Device Fabrication Having Copper Interconnects | Process For Making Compound Films | Process For Making Composite Films | Electro-Mechanical Device Having A Charge Dissipation Layer And A Method Of Manufacture Therefor | Electro-Mechanical Device Having A Charge Dissipation Layer And Method Of Manufacture Therefor | Process For Fabricating Vertical Transistors | Process For Fabricating Vertical Transistors | Phase-Shifting Mask And Semiconductor Device | Phase-Shifting Mask And Semiconductor Device | Phase-Shifting Mask And Semiconductor Device | Complementary Devices Using Thin Film Transistors With Improved Current Drive | Current Drive of TFTs in High\(miSpeed SRAMs | Process | Active Neural Network Determination Of Endpoint In A Plasma Etch | Active Neural Network Control Of Wafer Attributes In A Plasma Etch Process | Active Neural Network Control Of Water Attributes in a Masma etch Process | Mixed Signal Integrated Circuit With Improved Isolation | Mixed Signal Integrated Circuit With Improved Isolation | Real-Time Gate Etch Critical Dimension Control By Oxygen Monitoring | Real-Time Gate Etch Critical Dimension Control By Oxygen Monitoring | Method For Forming Metal Silicide Regions In An Integrated Circuit | |

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| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Inte |
| 09045062 | 6103615 | 1998-03-19 | 2000-08-15 | Granted | United States of America | Corrosion sensitivity structures for vias and contact holes in integrated circuits |
| 09/6/775 | 6279120 | 1999-17-15 | 16-80-1006 | Grantod | United States of America | Corrosion sensitivity structures for vias and contact holes in integrated |
| | 6525377 | 1999-08-09 | 2003-02-25 | | United States of America | Low threshold voltage MOS transistor and method of manufacture |
| | 5985705 | 1998-06-30 | 1999-11-16 | | United States of America | Low threshold voltage MOS transistor and method of manufacture |
| 09027307 | 6004880 | 1998-02-20 | 1999-12-21 | Granted | United States of America | Method of single step damascene process for deposition and global planarization |
| | 6090239 | 1999-08-02 | 2000-07-18 | Granted | United States of America | Method of single step damascene process for deposition and global planarization |
| 09052851 | 6057571 | 1998-03-31 | 2000-05-02 | Granted | United States of America | High aspect ratio, metal-to-metal, linear capacitor for an integrated circuit |
| 09221023 | 6251740 | 1998-12-23 | 2001-06-26 | Granted | United States of America | Method of forming and electrically connecting a vertical interdigitated metal-insulator-metal capacitor extending between interconnect layers in an integrated circuit |
| 09219655 | 6417535 | 1998-12-23 | 2002-07-09 | Granted | United States of America | Vertical interdigitated metal-insulator-metal capacitor for an integrated circuit |
| 09052793 | 6358837 | 1998-03-31 | 2002-03-19 | Granted | United States of America | Method of electrically connecting and isolating components with vertical elements extending between interconnect layers in an integrated circuit |
| 09525489 | 6441419 | 2000-03-15 | 2002-08-27 | Granted | United States of America | Encapsulated-metal vertical-interdigitated capacitor and damascene method of manufacturing same |
| 09517150 | 6479857 | 2000-03-02 | 2002-11-12 | Lapsed | United States of America | Capacitor having a tantalum lower electrode and method of forming the same |
| 10228859 | 6861310 | 2002-08-27 | 2005-03-01 | Lapsed | United States of America | Capacitor having a tantalum lower electrode and method of forming the same |
| | 6620729 | 2001-09-14 | 2003-09-16 | Lapsed | United States of America | Ion beam dual damascene process |
| 10400281 | 6168502 | 2003-03-27 | 2001-01-02 | Abandoned | United States of America United States of America | lon Beam Double Damascene Process Subsonic to supersonic and ultrasonic conditioning of a polishing pad in a chemical mechanical polishing apparatus |
| 08696445 | 5868608 | 1996-08-13 | 1999-02-09 | Expired | United States of America | Subsonic to supersonic and ultrasonic conditioning of a polishing pad in a chemical mechanical polishing apparatus |
| 60097750 | | 1998-08-24 | | Expired | United States of America | Off-Axis Pupil Aperture And Method For Making The Same |
| 09358606 | 6426131 | 1999-07-21 | 2002-07-30 | Granted | United States of America | Off-axis pupil aperture and method for making the same |
| 09844531 | 6596579 | 2001-04-27 | 2003-07-22 | Granted | United States of America | Method of forming analog capacitor dual damascene process |
| 10959868 | 7176082 | 2004-10-06 | 2007-02-13 | Granted | United States of America | Analog capacitor in dual damascene process |
| | 6822282 | 2003-04-08 | 2004-11-23 | Granted | United States of America | Analog capacitor in dual damascene process |
| 08578741 | | 1995-12-26 | | Abandoned | United States of America | Integrated Circuit With On-Chip Ground Plane |

| Incorporating dopants to enhance the dielectric properties of metal silicates | United States of America | Granted | 2007-12-25 | 2006-03-23 | 7312127 | 11389643 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| PROGRAMMABLE NANOTUBE INTERCONNECT | United States of America | Granted | 2013-04-09 | 2009-01-15 | 8415714 | 12354768 |
| PROGRAMMABLE NANOTUBE INTERCONNECT | United States of America | Granted | 2009-02-24 | 2005-11-23 | 7494842 | 11286546 |
| Method of making combined JFET & amp; MOS transistor device | United States of America | Expired | 1997-05-20 | 1996-03-06 | 5631176 | 08612337 |
| Combined JFET and MOS transistor device, circuit | United States of America | Expired | 1996-08-06 | 1995-07-13 | 5543643 | 08502566 |
| Method of Treating Metal and Metal Salts to Enable Thin Layer Deposition in Semiconductor Processing | United States of America | Lapsed | 2010-03-02 | 2007-11-13 | 7670645 | 11939482 |
| Method of vaporizing and ionizing metals for use in semiconductor processing | United States of America | Granted | 2008-01-29 | 2003-10-29 | 7323228 | 10697506 |
| Method and System for Reducing Inter-Layer Capacitance in Integrated Circuits | United States of America | Granted | 2011-09-06 | 2008-05-30 | 8015540 | 12156281 |
| Method and system for reducing inter-layer capacitance in integrated circuits | United States of America | Granted | 2008-07-08 | 2004-11-17 | 7396760 | 10991107 |
| Dielectric barrier films for use as copper barrier layers in semiconductor trench and via structures | United States of America | Granted | 2008-09-23 | 2005-05-16 | 7427563 | 11131003 |
| Dielectric barrier films for use as copper barrier layers in semiconductor trench and via structures | United States of America | Lapsed | 2005-09-06 | 2002-12-16 | 6939800 | 10321938 |
| Dielectric Barrier Films For Use As Copper Barrier Layers In Semiconductor Trench And Via Structures | United States of America | Granted | 2010-01-12 | 2008-08-13 | 7646077 | 12191171 |
| Psuedo Low Volume Reticle (PLVR) Design for ASIC Manufacturing | United States of America | Lapsed | 2010-07-27 | 2008-09-04 | 7763414 | 12204290 |
| Psuedo Low Volume Reticle (PLVR) Design for ASIC Manufacturing | United States of America | Abandoned | | 2004-09-20 | | 10944995 |
| Method and apparatus for forming dielectric films | United States of America | Expired | 1998-01-20 | 1996-05-24 | 5710079 | 08653264 |
| Method and apparatus for forming dielectric films | United States of America | Expired | 2000-02-29 | 1997-09-09 | 6030460 | 08926220 |
| Method for artificially-inducing reverse short-channel effects in deep submicron CMOS devices | United States of America | Expired | 1999-02-23 | 1996-12-05 | 5874329 | 08761761 |
| Deep Sub-Micron CMOS Device Exhibiting Artificially-Induced Reverse Short-Channel Effects | United States of America | Abandoned | | 1998-09-22 | | 09158408 |
| Method And Apparatus For Eliminating Peeling At End Edge Of Semiconductor Substrate In Metal Organic Chemical Vapor Deposition Of Titanium Nitrite | United States of America | Abandoned | | 1998-05-22 | | 09084027 |
| Method for eliminating peeling at end of semiconductor substrate in metal organic chemical vapor deposition of titanium nitride | United States of America | Expired | 1998-08-04 | 1997-03-04 | 5789028 | 08811818 |
| On-chip misalignment indication | United States of America | Expired | 2001-04-24 | 1998-09-09 | 6221681 | 09150076 |
| On-chip misalignment indication | United States of America | Expired | 1999-04-27 | 1997-10-03 | 5898228 | 08943371 |
| Integrated circuit with on-chip ground plane | United States of America | Expired | 1996-01-09 | 1994-07-19 | 5482897 | 08277344 |
| Integrated circuit with on-chip ground base | United States of America | Expired | 1999-04-06 | 1997-06-02 | 5892272 | 08867286 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 08939350 | 08695569 | 08374195 | 08677078 | | 08521795 | | | 08488075 | 08768845 | 08704472 | 08561107 | | 08438614 | 08879341 | 08604867 | 10772133 | 11733673 | 10035704 | 11046150 | 11768725 | 10738761 | AppNo |
|--|--|--|--------------------------|---|--------------------------|--|---|--|--------------------------------|--------------------------------|--------------------------|--|---|--|--|---|---|---|---|---|---|-----------|
| 5858864 | 5663083 | 5598021 | 5717238 | | 5585286 | | | 5583062 | 5770492 | 5763302 | 5650653 | | | 6081008 | 5688709 | 7229923 | 7413984 | 6727177 | 7258953 | 7492049 | 7064062 | PatentNo |
| 1997-09-29 | 1996-08-12 | 1995-01-18 | 1996-07-09 | | 1995-08-31 | | | 1995-06-07 | 1996-12-18 | 1996-08-20 | 1995-11-21 | | 1995-05-10 | 1997-06-20 | 1996-02-14 | 2004-02-03 | 2007-04-10 | 2001-10-18 | 2005-01-28 | 2007-06-26 | 2003-12-16 | FiledDate |
| 1999-01-12 | 1997-09-02 | 1997-01-28 | 1998-02-10 | | 1996-12-17 | | | 1996-12-10 | 1998-06-23 | 1998-06-09 | 1997-07-22 | | | 2000-06-27 | 1997-11-18 | 2007-06-12 | 2008-08-19 | 2004-04-27 | 2007-08-21 | 2009-02-17 | 2006-06-20 | GrantDate |
| Expired | Expired | Expired | Expired | | Expired | | | Expired | Expired | Expired | Expired | | Abandoned | Expired | Expired | Granted | Granted | Granted | Lapsed | Lapsed | Lapsed | Status |
| United States of America | United States of America | United States of America | United States of America | | United States of America | | | United States of America | United States of America | United States of America | United States of America | | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Country |
| Process for making group IV semiconductor substrate treated with one or more group IV elements to form barrier region capable of inhibiting migration of dopant materials in substrate | Process for making improved MOS structure with hot carrier reduction | MOS structure with hot carrier reduction | device | Substrate with controlled amount of noble gas ions to reduce channeling and/or diffusion of a boron dopant forming P-LDD region of a PMOS | PMOS device | noble gas ions to reduce channeling and/or diffusion of a boron dopant subsequently implanted into the substrate to form P-LDD region of a | Implantation of a semiconductor substrate with controlled amount of | Self-aligned twin well process having a SiO2-polysilicon-SiO2 barrier mask | Self-aligned twin well process | Self-aligned twin well process | device | Microelectronic integrated circuit including triangular CMOS nand gate | Microelectronic Integrated Circuit Including Triangular Semiconductor " Nand" Gate Device | Composite trench-fin capacitors for DRAM | Method for forming composite trench-fin capacitors for DRAMS | Multi-step process for forming a barrier film for use in copper layer formation | Multi-step process for forming a barrier film for use in copper layer formation | Multi-step process for forming a barrier film for use in copper layer formation | Multi-layer registration and dimensional test mark for scatterometrical measurement | Multi-layer Registration and Dimensional Test Mark for Scatterometrical Measurement | Incorporating dopants to enhance the dielectric properties of metal silicates | Title |

| 1994-09-13 | AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|--|----------|----------|------------|------------|-----------|--------------------------|---|
| | 08306179 | | 1994-09-13 | 3 | oned | United States of America | Group Iv Semiconductor Substrate Treated With One Or More Group Iv Elements To Form Barrier Region Capable Of Inhibiting Migration Of Dopant Materials In Substrate And Process For Making Same |
| 2004-03-01 Abandoned United States of America 7955919 2007-12-19 2011-06-07 Granted United States of America 1991-08-19 Abandoned United States of America 1992-03-27 2000-06-27 Expired United States of America 1993-02-04 Abandoned United States of America 1993-02-04 Abandoned United States of America 2001-19-20 Granted United States of America 2001-11-14 2006-02-21 Lapsed United States of America 2003-02-05 2003-02-05 2003-04-22 Granted United States of America 2003-03-04-11 2006-08-29 Lapsed United States of America 2003-03-24 2003-04-25 Granted United States of America 2003-03-24 2003-03-25 Granted United States of America 2003-03-24 2003-03-25 Lapsed United States of America 2003-03-25 2003-03-2 | 08434673 | 5654210 | 1995-05-04 | | Expired | United States of America | Process for making group IV semiconductor substrate treated with one or more group IV elements to form one or more barrier regions capable of inhibiting migration of dopant materials in substrate |
| | 10791337 | | 2004-03-01 | | ned | United States of America | Spacer-Less Transistor Integration Scheme For High-K Gate Dielectrics And Small Gate-To-Gate Spaces Applicable To SI, SIGe And Strained Silicon Schemes |
| 7955919 2007-12-19 2011-06-07 Granted United States of America | | | | | | | Spacer-Less Transistor Integration Scheme For High-K Gate Dielectrics And Small Gate-To-Gate Spaces Applicable To Si, SiGe And Strained Silicon |
| 1991-08-19 | 11960554 | 7955919 | 2007-12-19 | 2011-06-07 | Granted | United States of America | Schemes |
| 6081004 1995-03-27 2000-06-27 Expired United States of America 6081004 1995-03-21 2000-06-27 Expired United States of America 8021955 2009-10-06 2011-09-20 Granted United States of America 7619294 2009-10-06 2011-09-20 Granted United States of America 7001823 2001-11-1 2006-02-21 Lapsed United States of America 7098515 2003-01-01 Abandoned United States of America 7098515 2005-04-11 2006-02-21 Lapsed United States of America 7098515 2005-03-24 2007-12-25 Granted United States of America 703329 2005-03-24 2007-12-25 Granted United States of America 7033929 2002-12-23 2006-04-25 Iapsed United States of America 6432759 1994-06-14 2002-08-13 Granted United States of America 7582938 2005-10-25 2009-09-01 Iapsed United States of America | 07754201 | | 1991-08-19 | | | United States of America | Bicmos Compacted Logic Array |
| 1990-05-14 Abandoned United States of America 1993-02-04 Abandoned United States of America 1993-02-04 Abandoned United States of America 1993-02-04 2009-10-05 2011-09-20 Granted United States of America 2009-10-12 2009-11-17 2009-11-17 2009-11-17 2009-11-17 2009-11-17 2009-02-21 2009-01-01 Abandoned United States of America 2009-11-14 2009-09-05-17 Granted United States of America 2009-11-18 2009-09-09-09-09-09-09-09-09-09-09-09-09- | 08410375 | 6081004 | 1995-03-27 | 2000-06-27 | Expired | United States of America | BiCMOS compacted logic array |
| 1993-02-04 1993-02-04 2011-09-20 Granted United States of America 2009-10-06 2011-09-20 Granted United States of America 2009-11-17 Lapsed United States of America 2001-11-14 2006-02-21 Lapsed United States of America 2001-11-14 2006-02-21 Lapsed United States of America 2003-02-05 2003-02-05 2003-02-05 2003-02-05 2003-02-05 2003-02-05 2003-02-05 2003-04-22 2003-04-22 2003-04-22 2003-04-22 2003-04-22 2003-04-22 2003-04-22 2003-04-22 2003-04-25 200 | 07523445 | | 1990-05-14 | | Abandoned | United States of America | Bicmos Compacted Logic Array |
| R021955 2009-10-06 2011-09-20 Granted United States of America | 08014084 | | 1993-02-04 | | Abandoned | United States of America | Bicmos Compacted Logic Array |
| 7619294 2005-10-28 2009-11-17 Lapsed United States of America 7001823 2001-11-14 2006-02-21 Lapsed United States of America 1900-01-01 Lapsed United States of America 6893937 2003-02-05 2005-05-17 Granted United States of America 7098515 2005-04-11 2006-08-29 Lapsed United States of America 6551901 2001-11-30 2003-04-22 Granted United States of America 7312532 2005-03-24 2007-12-25 Granted United States of America 7033929 2002-12-23 2006-04-25 Lapsed United States of America 6432759 1994-06-14 2002-08-13 Granted United States of America 7582938 2005-10-25 2009-09-01 Lapsed United States of America | 12574426 | 8021955 | 2009-10-06 | 2011-09-20 | Granted | United States of America | Method Characterizing Materials For A Trench Isolation Structure Having Low Trench Parasitic Capacitance |
| 7001823 2001-11-14 2006-02-21 Lapsed United States of America 6893937 2003-02-05 2005-05-17 Granted United States of America 7098515 2005-04-11 2006-08-29 Lapsed United States of America 6551901 2001-11-30 2003-04-22 Granted United States of America 7312532 2005-03-24 2007-12-25 Granted United States of America 7033929 2002-12-23 2006-04-25 Lapsed United States of America 6432759 1994-06-14 2002-08-13 Granted United States of America 7582938 2005-10-25 2009-09-01 Lapsed United States of America | 11262173 | 7619294 | 2005-10-28 | 2009-11-17 | Lapsed | United States of America | Shallow Trench Isolation Structure With Low Trench Parasitic Capacitance |
| 1900-01-01 Abandoned United States of America | 09991202 | 7001823 | 2001-11-14 | 2006-02-21 | Lapsed | United States of America | Method of manufacturing a shallow trench isolation structure with low trench parasitic capacitance |
| 6893937 2003-02-05 2005-05-17 Granted United States of America 7098515 2005-04-11 2006-08-29 Lapsed United States of America 6551901 2001-11-30 2003-04-22 Granted United States of America 7312532 2005-03-24 2007-12-25 Granted United States of America 7033929 2002-12-23 2006-04-25 Lapsed United States of America 6432759 1994-06-14 2002-08-13 Granted United States of America 7582938 2005-10-25 2009-09-01 Lapsed United States of America | 60314148 | | 1900-01-01 | | Abandoned | United States of America | |
| 7098515 2005-04-11 2006-08-29 Lapsed United States of America 6551901 2001-11-30 2003-04-22 Granted United States of America 7312532 2005-03-24 2007-12-25 Granted United States of America 7033929 2002-12-23 2006-04-25 Lapsed United States of America 6432759 1992-11-24 Abandoned United States of America 7582938 2005-10-25 2009-09-01 Lapsed United States of America | 10360746 | 6893937 | 2003-02-05 | 2005-05-17 | Granted | | Method for preventing borderless contact to well leakage |
| 6551901 2001-11-30 2003-04-22 Granted United States of America | 11104050 | 7098515 | 2005-04-11 | 2006-08-29 | Lapsed | United States of America | Semiconductor chip with borderless contact that avoids well leakage |
| 7312532 2005-03-24 2007-12-25 Granted United States of America 7033929 2002-12-23 2006-04-25 Lapsed United States of America 1992-11-24 Abandoned United States of America 6432759 1994-06-14 2002-08-13 Granted United States of America 7582938 2005-10-25 2009-09-01 Lapsed United States of America | 10006540 | 6551901 | 2001-11-30 | 2003-04-22 | Granted | United States of America | Method for preventing borderless contact to well leakage |
| 7033929 2002-12-23 2006-04-25 Lapsed United States of America 1992-11-24 Abandoned United States of America 6432759 1994-06-14 2002-08-13 Granted United States of America 7582938 2005-10-25 2009-09-01 Lapsed United States of America | 11090107 | 7312532 | 2005-03-24 | 2007-12-25 | Granted | United States of America | Dual damascene interconnect structure with improved electro migration lifetimes |
| 1992-11-24 Abandoned United States of America 6432759 1994-06-14 2002-08-13 Granted United States of America 7582938 2005-10-25 2009-09-01 Lapsed United States of America | 10328333 | 9265507 | 2002-12-23 | | Lapsed | United States of America | Dual damascene interconnect structure with improved electro migration lifetimes |
| 6432759 1994-06-14 2002-08-13 Granted United States of America Method 7582938 2005-10-25 2009-09-01 Lapsed United States of America Deep-Su | 07982093 | | 1992-11-24 | | Abandoned | United States of America | Improved Metal Oxide Semiconductors Devices And Method For Making Same |
| 7582938 2005-10-25 2009-09-01 Lapsed United States of America Deep-Su | 08259575 | 6432759 | 1994-06-14 | 2002-08-13 | Granted | | Method of forming source and drain regions for CMOS devices |
| | 11258253 | 7582938 | 2005-10-25 | 2009-09-01 | Lapsed | United States of America | I/O and Power ESD Protection Circuits by Enhancing Substrate-Bias In Deep-Submicron CMOS Process |

| | United States of America | | בר זה זהחה | 2004-00-20 | 7060130 | 10000 |
|--|---------------------------------------|-----------|------------|------------|---------|----------|
| Inductor Formed In An Integrated Circuit | United States of America | Granted | 2009-06-02 | 2006-05-01 | 7541738 | 11414902 |
| Yield Profile Manipulator | United States of America | Granted | 2011-04-19 | 2008-05-08 | 7930655 | 12117379 |
| Yield profile manipulator | United States of America | Granted | 2008-07-01 | 2004-03-16 | 7395522 | 10801310 |
| Local interconnect for integrated circuit | United States of America | Lapsed | 2006-07-25 | 2005-02-15 | 7081379 | 11058498 |
| Local interconnect for integrated circuit | United States of America | Lapsed | 2005-03-29 | 2003-03-06 | 6872612 | 10383149 |
| Method and apparatus for redirecting void diffusion away from vias in an integrated circuit design | United States of America | Granted | 2008-04-22 | 2005-12-29 | 7361965 | 11323400 |
| | United States of America | Lapsed | 2009-09-01 | 2008-01-24 | 7582566 | 12018849 |
| Bipolar Device Having Improved Capacitance | United States of America | Lapsed | 2010-02-23 | 2006-09-13 | 7666750 | 11531477 |
| Bipolar Device Having Improved Capacitance | United States of America | Granted | 2012-01-31 | 2010-01-05 | 8106480 | 12652560 |
| Digitally Obtaining Contours of Fabricated Polygons | United States of America | Granted | 2010-11-02 | 2005-07-15 | 7827509 | 11182615 |
| Digitally Obtaining Contours of Fabricated Polygons | United States of America | Lapsed | 2013-09-03 | 2010-09-24 | 8527912 | 12890336 |
| Voltage contrast monitor for integrated circuit defects | United States of America | Lapsed | 2008-01-29 | 2005-05-18 | 7323768 | 11131705 |
| Voltage contrast monitor for integrated circuit defects | United States of America | Lapsed | 2005-08-30 | 2003-08-29 | 6936920 | 10652369 |
| Voltage Contrast Monitor for Integrated Circuit Defects | United States of America | Lapsed | 2009-07-14 | 2007-11-08 | 7560292 | 11937199 |
| Apparatus for conducting a refractory metal deposition process | United States of America | Expired | 1993-01-19 | 1990-10-02 | 5180432 | 07592014 |
| Tungsten Deposition Process For Low Contact Resistivity To Silicon | United States of America | Abandoned | | 1990-01-08 | | 07461959 |
| Gas control technique for limiting surging of gas into a CVD chamber | United States of America | Expired | 1998-12-29 | 1997-05-06 | 5853804 | 08851846 |
| Tungsten deposition process for low contact resistivity to silicon | United States of America | Expired | 1995-02-21 | 1991-07-29 | 5391394 | 07739773 |
| In-Situ Etch Of Cvd Chamber | United States of America | Abandoned | | 1997-11-26 | | 08979734 |
| Apparatus for performing in-situ etch of CVD chamber | United States of America | Expired | 1993-05-18 | 1991-12-12 | 5211796 | 07809104 |
| Apparatus For Performing In-Situ Etch Of Of A Cvd Chamber | United States of America | Abandoned | | 1990-10-02 | | 07591655 |
| Method for performing in-situ etch of a CVD chamber | United States of America | Expired | 1993-04-20 | 1991-11-18 | 5203956 | 07794780 |
| Method For Performing In-Situ Etch Of A Cvd Chamber | United States of America | Abandoned | | 1990-10-02 | | 07591587 |
| Filtering technique for CVD chamber process gases | United States of America | Expired | 1997-10-28 | 1995-02-17 | 5681613 | 08390329 |
| Purging gas control structure for CVD chamber | United States of America | Expired | 2000-09-05 | 1997-11-26 | 6113699 | 08979733 |
| Structure for filtering CVD chamber process gases | United States of America | Expired | 1992-06-23 | 1990-10-02 | 5123375 | 07591646 |
| Circuits and Methods for Improved FET Matching | United States of America | Granted | 2013-05-14 | 2012-02-08 | 8440512 | 13368985 |
| Circuits And Methods For Improved FET Matching | United States of America | Granted | 2012-03-13 | 2007-08-14 | 8134188 | 11838546 |
| Substrate-biased I/O and power ESD protection circuits in deep-submicron twin-well process | United States of America | Granted | 2005-12-27 | 2003-10-01 | 6979869 | 10676602 |
| I/O and Power ESD Protection Circuits by Enhancing Substrate-Bias In Deep-Submicron CMOS Process | United States of America | Granted | 2012-09-18 | 2011-05-18 | 8269280 | 13110581 |
| I/O and Power ESD Protection Circuits by Enhancing Substrate-Bias In Deep-Submicron CMOS Process | United States of America | Granted | 2011-05-24 | 2009-07-21 | 7948036 | 12506746 |
| | e e e e e e e e e e e e e e e e e e e | 0,0,00 | 0.0 | - STEP | () | |

| High K Dielectric Material And Method Of Making A High K Dielectric Material | United States of America | Lapsed | 2004-01-20 | 2002-05-28 | 6680130 | 10155173 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| High K Dielectric Material And Method Of Making A High K Dielectric Material | United States of America | Lapsed | 2008-11-25 | 2003-11-24 | 7456064 | 10718536 |
| Method Of Verifying IC Mask Sets | United States of America | Lapsed | 2006-09-05 | 2002-12-11 | 7103869 | 10317147 |
| Apparatus For Verification Of IC Mask Sets | United States of America | Granted | 2003-03-04 | 2000-03-17 | 6530074 | 09528071 |
| Method For Making A Radio Frequency Component And Component Produced Thereby | United States of America | Granted | 2004-06-01 | 2000-11-17 | 6743731 | 09715651 |
| Method For Making A Radio Frequency Component And Component Produced Thereby | United States of America | Abandoned | | 2004-04-21 | | 10828993 |
| A Thermally Stable BiCMOS Fabrication Method And Bipolar Junction Transistor Formed According To The Method | United States of America | Granted | 2011-12-27 | 2010-07-08 | 8084313 | 12832110 |
| A Thermally Stable BiCMOS Fabrication Method And Bipolar Junction Transistors Formed According To The Method | United States of America | Lapsed | 2008-10-21 | 2006-02-24 | 7439119 | 11361430 |
| A Thermally Stable BiCMOS Fabrication Method And Bipolar Junction Transistors Formed According To The Method | United States of America | Lapsed | 2010-08-17 | 2008-09-11 | 7776678 | 12208929 |
| A High Dopant Concentration Diffused Resistor And Method Of Manufacture Thereof | United States of America | Granted | 2004-02-10 | 2002-09-27 | 6690082 | 10256466 |
| High Dopant Concentration Diffused Resistor And Method Of Manufacture Thereof | United States of America | Granted | 2004-08-31 | 2003-09-24 | 6784044 | 10669398 |
| A Bipolar Junction Transistor Having A High Germanium Concentration In A Silicon-Germanium Layer and a Method for Forming the Bipolar Junction Transistor | United States of America | Abandoned | | 2012-01-11 | | 13348415 |
| A Bipolar Junction Transistor Having A High Germanium Concentration In A Silicon-Germanium Layer And A Method For Forming The Bipolar Junction Transistor | United States of America | Lapsed | 2010-05-11 | 2006-08-21 | 7714361 | 10598213 |
| A Bipolar Junction Treatment Having A High Germanium Concentration In A Silicon Germanium Layer and a Method for Forming the Bipolar Junction Transistor | United States of America | Granted | 2012-07-24 | 2010-03-22 | 8227319 | 12728412 |
| Method to selectively identify reliability risk die based on characteristics of local regions on the wafer | United States of America | Granted | 2008-06-24 | 2005-01-06 | 7390680 | 11031564 |
| Method to selectively identify reliability risk die based on characteristics of local regions on the wafer | United States of America | Lapsed | 2005-04-12 | 2003-06-04 | 6880140 | 10454027 |
| Interdigitated Capacitors | United States of America | Granted | 2011-10-18 | 2009-11-10 | 8039923 | 12616050 |
| Interdigitated Capacitors | United States of America | Granted | 2006-04-04 | 2004-07-08 | 7022581 | 10886763 |
| Interdigitated Capacitors | United States of America | Granted | 2009-12-22 | 2005-11-02 | 7635888 | 11265062 |
| Inductor Formed In An Integrated Circuit | United States of America | Granted | 2010-03-16 | 2008-12-22 | 7678639 | 12340813 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

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|----------|---------|------------|------------|-----------|--------------------------|---|
| 12506090 | 7981305 | 2009-07-20 | 2011-07-19 | Granted | United States of America | High Density Field Emission Elements And A Method For Forming Said Emission Elements |
| 11057690 | 7564178 | 2005-02-14 | 2009-07-21 | Lapsed | United States of America | High Density Field Emission Elements and a Method for Forming Said Emission Elements |
| 09901073 | | 2001-07-09 | | Abandoned | United States of America | Lateral High-Q Inductor For Semiconductor Devices |
| 09416348 | 6292086 | 1999-10-12 | 2001-09-18 | Granted | United States of America | Lateral High-Q Inductor For Semiconductor Devices |
| 09894116 | 6458016 | 2001-06-28 | 2002-10-01 | Granted | United States of America | Polishing Fluid, Polishing Method, Semiconductor Device And Semiconductor Device Fabrication Method |
| 09483576 | 6375541 | 2000-01-14 | 2002-04-23 | Granted | United States of America | Polishing Fluid, Polishing Method, Semiconductor Device and Semiconductor Device Fabrication Method |
| 10637385 | 7067048 | 2003-08-08 | 2006-06-27 | Lapsed | United States of America | Method to improve the control of electro-polishing by use of a plating electrode an electrolyte bath |
| 11409377 | | 2006-04-21 | | Abandoned | United States of America | Method To Improve The Control Of Electro-Polishing By Use Of A Plating Electrode In An Electrolyte Bath |
| 10152879 | | 2002-05-21 | | Abandoned | United States of America | Microsrtructure Control Of Copper Interconnects |
| 09419986 | 6440849 | 1999-10-18 | 2002-08-27 | Granted | United States of America | Microsrtructure Control Of Copper Interconnects |
| 08814051 | 5936831 | 1997-03-06 | 1999-08-10 | Expired | United States of America | Thin Film Tantalum Oxide Capacitors And Resulting Product |
| 08918174 | 6075691 | 1997-08-25 | 2000-06-13 | Expired | United States of America | THIN FILM CAPACITORS AND PROCESS FOR MAKING THEM |
| 08678971 | 5821148 | 1996-07-12 | 1998-10-13 | Expired | United States of America | Method of Fabricating a Segmented Emitter Low Noise Transistor |
| 08484675 | 5723897 | 1995-06-07 | 1998-03-03 | Expired | United States of America | Segmented Emitter Low Noise Transistor |
| 09653616 | 6690037 | 2000-08-31 | 2004-02-10 | Granted | United States of America | Field Plated Schottky Diode |
| 10696136 | 6790753 | 2003-10-29 | 2004-09-14 | Granted | United States of America | Field Plated Schottky Diode And Method Of Fabrication Thereof |
| 09878657 | 6482694 | 2001-06-11 | 2002-11-19 | Granted | United States of America | Semiconductor Device Structure Including A Tantalum Pentoxide Layer Sandwiched Between Silicon Nitride Layers |
| 09259001 | 6294807 | 1999-02-26 | 2001-09-25 | Granted | United States of America | Semiconductor Device Structure Including A Tantalum Pentoxide Layer Sandwiched Between Silicon Nitride Layers |
| 11649197 | 7670203 | 2007-01-03 | 2010-03-02 | Lapsed | United States of America | Process For Making An On-Chip Vacuum Tube Device |
| 09651696 | 7259510 | 2000-08-30 | 2007-08-21 | Granted | United States of America | On-Chip Vacuum Tube Device And Process For Making Device |
| 09643784 | 6383923 | 2000-08-22 | 2002-05-07 | Granted | United States of America | Article Comprising Vertically Nano-InterConnected Circuit Devices And Method For Making The Same |
| 09426457 | 6340822 | 1999-10-05 | 2002-01-22 | Granted | United States of America | Article Comprising Vertically Nano-InterConnected Circuit Devices And Method For Making The Same |
| 11748569 | 7407824 | 2007-05-15 | 2008-08-05 | Granted | United States of America | Guard Ring For Improved Matching |
| 10941665 | 7253012 | 2004-09-14 | 2007-08-07 | Granted | United States of America | Guard Ring For Improved Matching |
| 10916322 | 7405116 | 2004-08-11 | 2008-07-29 | Granted | United States of America | Application of gate edge liner to maintain gate length CD in a replacement gate transistor flow |
| 12140773 | 8384165 | 2008-06-17 | 2013-02-26 | Granted | United States of America | Application of Gate Edge Liner To Maintain Gate Length CD In A Replacement Gate Transistor Flow |

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| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
| 09410686 | 6410435 | 1999-10-01 | 2002-06-25 | Granted | United States of America | Process For Fabricating Copper Interconnect For ULSI Integrated Circuits |
| 10120707 | | 2002-04-11 | | Abandoned | United States of America | Process For Fabricating Copper Interconnect For ULSI Integrated Circuits |
| 12356600 | 8022481 | 2009-01-21 | 2011-09-20 | Granted | United States of America | Robust Shallow Trench Isolation Structures And A Method For Forming Shallow Trench Isolation Structures |
| | | | | | | Robust Shallow Trench Isolation Structures And A Method For Forming |
| 11321206 | 7514336 | 2005-12-29 | 2009-04-07 | Lapsed | United States of America | Shallow Trench Isolation Structures |
| 09280103 | 6252245 | 1999-03-29 | 92-90-1005 | Granted | United States of America | Device Comprising N-Channel Semiconductor Material |
| 09476511 | 6387727 | 2000-01-03 | 2002-05-14 | Granted | United States of America | Device Comprising N-Channel Semiconductor Material |
| 11927950 | 7579245 | 2007-10-30 | 2009-08-25 | Lapsed | United States of America | Dual-Gate Metal-Oxide Semiconductor Device |
| 10999705 | 7329922 | 2004-11-30 | 2008-02-12 | Granted | United States of America | Dual\(miGate Metal\(miOxide Semiconductor Device |
| 09887736 | 9500269 | 2001-06-19 | 91-80-5000 | 2000 | United States of America | Plasma treatment of low dielectric constant dielectric material to form structures useful in formation of metal interconnects and/or filled vias for integrated circuit structure |
| 10422270 | 6790784 | 2003-04-24 | 2004-09-14 | Lapsed | United States of America | Plasma treatment of low dielectric constant dielectric material to form structures useful in formation of metal interconnects and/or filled vias for intergrated circuit structure |
| 11530550 | 7271485 | 2006-09-11 | 2007-09-18 | Granted | United States of America | Systems And Methods For Distributing I\(sIO In A Semiconductor Device |
| 11684674 | 7709861 | 2007-03-12 | 2010-05-04 | Granted | United States of America | Systems And Methods For Supporting a Subset of Multiple Interface Types In A Semiconductor Device |
| 09456224 | 6576529 | 1999-12-07 | 2003-06-10 | Granted | United States of America | A Method Of Forming An Alignment Feature In Or On A Multi-Layered Semiconductor Structure |
| 10704449 | 6977128 | 2003-11-07 | 2005-12-20 | Lapsed | United States of America | Multi-Layered Semiconductor Structure |
| 09867202 | 6706609 | 2001-05-29 | 2004-03-16 | Granted | United States of America | Method Of Forming An Alignment Feature In Or On A Multi-Layered Semiconductor Structure |
| 09804783 | 6586326 | 2001-03-13 | 2003-07-01 | Lapsed | United States of America | Metal planarization system |
| 10400278 | 6951808 | 2003-03-27 | 2005-10-04 | Lapsed | United States of America | Metal planarization system |
| 09617550 | 6569751 | 2000-07-17 | 2003-05-27 | Granted | United States of America | Low via resistance system |
| 10400252 | 6893962 | 2003-03-27 | 2005-05-17 | Granted | United States of America | Low via resistance system |
| 08718113 | 5804975 | 1996-09-18 | 80-60-8661 | Expired | United States of America | Detecting Breakdown In Dielectric Layers |
| 09002497 | 6043662 | 1998-01-02 | 82-20-0002 | Expired | United States of America | Detecting Defects In Integrated Circuits |
| 08702073 | 5969376 | 1996-08-23 | 1999-10-19 | Expired | United States of America | An Organic Thin Film Transistor Having A Phthalocyanine Semiconductor Layer |
| 09704007 | 6150191 | 1998-17-01 | 2000-11-21 | Expired | United States of America | Method of Making an Organic Thin Film Transistor and Article Made by the Method |
| 09135260 | | 1998-08-17 | 2000-01-18 | Expired | United States of America | Method Of Forming Planarized Layers In An Intergrated Circuit |

| Silicon germanium CMOS channel | United States of America | Granted | 2003-04-08 | 2000-11-28 | 6544854 | 09724444 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Silicon germanium CMOS channel | United States of America | Lapsed | 2005-12-20 | 2003-02-18 | 6977400 | 10368811 |
| Method For Fabricating MOS Device With Halo Implanted Region | United States of America | Granted | 2002-03-26 | 2000-03-13 | 6362054 | 09523782 |
| Method For Fabricating MOS Device With Halo Implanted Region | United States of America | Granted | 2004-07-13 | 2001-12-31 | 6762459 | 10038734 |
| Process For Making Mixed Metal Oxides | United States of America | Granted | 2003-04-01 | 2001-07-27 | 6540974 | 09917365 |
| Thin Film Deposition Of Mixed Metal Oxides | United States of America | Granted | 2001-11-06 | 2000-03-23 | 6312565 | 09533428 |
| Method for creating self-aligned alloy capping layers for copper interconnect structures | United States of America | Granted | 2003-05-20 | 2001-11-01 | 6566262 | 10004461 |
| Self-aligned alloy capping layers for copper interconnect structures | United States of America | Granted | 2004-06-08 | 2003-02-18 | 6747358 | 10368760 |
| Field Emission Devices Employing Diamond Particle Emitters | United States of America | Expired | 1999-11-02 | 1998-01-13 | 5977697 | 09006347 |
| Particle Emitters | United States of America | Expired | 1998-01-20 | 1994-12-22 | 5709577 | 08361616 |
| Method Of Making Field Emission Devices Employing Ultra-Fine Diamond | | | | | | |
| Field Emission Devices Employing Activated Diamond Particle Emitters And Methods For Making Same | United States of America | Expired | 1997-04-01 | 1995-01-31 | 5616368 | 08381375 |
| Local interconnect | United States of America | Granted | 2003-06-10 | 2001-09-28 | 6576544 | 09966464 |
| Local interconnect | United States of America | Lapsed | 2005-08-09 | 2003-03-27 | 6927494 | 10400279 |
| A Micromagnetic Device For Power Processing Applications And Method Of Manufacture Therefor | United States of America | Expired | 2000-12-12 | 2000-01-24 | 6160721 | 09490655 |
| A Micromagnetic Device For Data Transmission Applications And Method Of Manufacture Therefor | United States of America | Expired | 2000-12-19 | 1998-07-02 | 6163234 | 09109963 |
| Integrated Circuit Having A Micromagnetic Device And Method Of Manufacture Therefor | United States of America | Expired | 2004-02-24 | 2001-10-15 | 6696744 | 09978871 |
| Micromagnetic Device For Power Processing Applications And Method Of Manufacture Therefor | United States of America | Lapsed | 2006-04-04 | 2003-03-13 | 7021518 | 10387846 |
| Method Of Making Integrated Circuit Having A Micromagnetic Device | United States of America | Expired | 2002-08-27 | 2000-02-23 | 6440750 | 09511343 |
| Micromagnetic Device Having An Anisotropic Ferromagnetic Core and Method of Manufacture Therefor | United States of America | Expired | 2001-02-20 | 1999-04-16 | 6191495 | 09292860 |
| A Micromagnetic Device For Power Processing Applications And Method Of Manufacture Therefor | United States of America | Expired | 2000-09-12 | 1997-06-10 | 6118351 | 08872250 |
| Single-Polysilicon CMOS Active Pixel Image Sensor | United States of America | Expired | 1998-11-10 | 1996-07-03 | 5835141 | 08675026 |
| Single-Polysilicon CMOS Active Pixel | United States of America | Expired | 1996-11-19 | 1994-11-22 | 5576763 | 08344785 |
| A Method Of Eliminating Agglomerate Particles In A Polishing Slurry | United States of America | Granted | 2004-06-15 | 2001-11-14 | 6750145 | 09992135 |
| A Method Of Eliminating Agglomerate Particles In A Polishing Slurry | United States of America | Granted | 2002-03-12 | 1999-10-26 | 6355184 | 09427306 |
| Method Of Eliminating Agglomerate Particles In A Polishing Slurry | United States of America | Granted | 2000-02-15 | 1998-05-21 | 6024829 | 09083072 |
| Method of Forming Planarized Layers In An Integrated Circuit | United States of America | Expired | 1998-11-17 | 1996-12-18 | 5836805 | 08769717 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Low k polymer E-beam printable mechanical support | United States of America | Lapsed | 2005-12-06 | 2002-12-23 | 6972217 | 10328614 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Exhaust flow control system | United States of America | Granted | 2003-06-17 | 2000-09-20 | 6579371 | 09666507 |
| Exhaust flow control system | United States of America | Granted | 2004-09-07 | 2002-07-17 | 6787180 | 10196787 |
| Film Substrates | United States of America | Abandoned | | 2001-02-01 | | 09775223 |
| Apparatus for removing photoresist edge beads from thin film substrates | United States of America | Granted | 2003-09-02 | 2002-10-03 | 6614507 | 10263593 |
| Method and apparatus for removing photoresist edge beads from thin film substrates | United States of America | Granted | 2002-12-17 | 2001-06-12 | 6495312 | 09879642 |
| Memory device having an electron trapping layer in a high-K dielectric gate stack | United States of America | Lapsed | 2006-01-24 | 2003-10-31 | 6989565 | 10698169 |
| Method and apparatus for forming a memory structure having an electron affinity region | United States of America | Granted | 2006-11-07 | 2002-04-15 | 7132336 | 10123263 |
| Memory Device Having an Electron Trapping Layer in a High-K Dielectric Gate Stack | United States of America | Abandoned | | 2005-07-25 | | 11189625 |
| Via and metal line interface capable of reducing the incidence of electro- migration induced voids | United States of America | Granted | 2005-04-05 | 2003-03-26 | 6875693 | 10400297 |
| Via and Metal Line Interface Capable of Reducing the Incidence of Electro- Migration Induced Voids | United States of America | Abandoned | | 2004-10-12 | | 10964032 |
| Polishing Fluid, Polishing Method, Semiconductor Device And Semiconductor Device Fabrication Method | United States of America | Granted | 2001-12-11 | 2000-01-14 | 6328633 | 09483785 |
| Polishing Fluid, Polishing Method, Semiconductor Device And Semiconductor Device Fabrication Method | United States of America | Granted | 2002-08-27 | 2001-06-28 | 6439972 | 09894117 |
| Planarization with Reduced Dishing | United States of America | Abandoned | | 2007-04-02 | | 11695169 |
| Planarization with reduced dishing | United States of America | Lapsed | 2006-04-18 | 2003-04-23 | 7029591 | 10421068 |
| Planarization with reduced dishing | United States of America | Granted | 2007-05-22 | 2006-01-23 | 7220362 | 11337460 |
| High k gate insulator removal | United States of America | | 2008-08-19 | 2003-04-14 | 7413996 | 10413051 |
| Plasma Removal Of High K Metal Oxide | United States of America | ned | | 2004-09-28 | | 10951646 |
| Variable mask field exposure | United States of America | | 2006-03-28 | 2003-05-05 | 7018753 | 10429376 |
| Variable Mask Field Exposure | United States of America | _ | 2009-12-29 | 2008-07-03 | 7638245 | 12167381 |
| Variable Mask Field Exposure | United States of America | Abandoned | | 2005-12-21 | | 11314649 |
| Interconnect integration | United States of America | Granted | 2004-08-17 | 2003-05-29 | 6777807 | 10448082 |
| Interconnect Integration | United States of America | Abandoned | | 2004-03-17 | | 10802522 |
| Method and structure for creating ultra low resistance damascene copper wiring | United States of America | Granted | 2007-03-27 | 2005-10-26 | 7196420 | 11259965 |
| Method and structure for creating ultra low resistance damascene copper wiring | United States of America | Granted | 2006-01-17 | 2003-08-14 | 6987059 | 10641768 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 10185537 6699766 | 10012847 6716364 | 09467622 6375791 | 11403137 7201176 | 10417708 7056392 | 09661465 6489242 | 10253158 6713394 | 10458141 6737342 | 10160812 6613637 | 10200469 6753255 | 10821708 | 60381746 | 10197956 6807655 | 10272767 6642597 | 10623082 7160805 | 09550381 6545305 | 09074837 6090656 | 11075195 7098996 | 11473627 7298458 | 10243562 6885436 | 11225310 7358594 | AppNo PatentNo |
|---|---|---|---|--|--|--|---|---|--|--|--|---|--|--|--|--|---|---|---|---|----------------|
| | | | | | | | | | | 2 | 2 | | | | | | | | | | |
| 2002-07-01 | 2001-12-10 | 1999-12-20 | 2006-04-11 | 2003-04-16 | 2000-09-13 | 2002-09-24 | 2003-06-09 | 2002-05-31 | 2002-07-18 | 2004-04-09 | 2002-05-17 | 2002-07-16 | 2002-10-16 | 2003-07-17 | 2000-04-14 | 1998-05-08 | 2005-03-07 | 2006-06-22 | 2002-09-13 | 2005-09-12 | FiledDate |
| 2004-03-02 | 2004-04-06 | 2002-04-23 | 2007-04-10 | 2006-06-06 | 2002-12-03 | 2004-03-30 | 2004-05-18 | 2003-09-02 | 2004-06-22 | | | 2004-10-19 | 2003-11-04 | 2007-01-09 | 2003-04-08 | 2000-07-18 | 2006-08-29 | 2007-11-20 | 2005-04-26 | 2008-04-15 | GrantDate |
| Granted | Granted | Granted | Granted | Lapsed | Granted | Granted | Granted | Granted | Granted | Abandoned | Expired | Lapsed | Granted | Granted | Granted | Granted | Lapsed | Granted | Lapsed | Granted | Status |
| United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Country |
| Method of fabricating an integral capacitor and gate transistor having nitride and oxide polish stop layers using chemical mechanical polishing elimination | Method and apparatus for detecting presence of residual polishing slurry subsequent to polishing of a semiconductor wafer | Method and apparatus for detecting presence of residual polishing slurry subsequent to polishing of a semiconductor wafer | Wafer chucking apparatus for spin processor | Wafer chucking apparatus and method for spin processor | Process for planarization of integrated circuit structure which inhibits cracking of low dielectric constant dielectric material adjacent underlying raised structures | Process for planarization of integrated circuit structure which inhibits cracking of low dielectric constant dielectric material adjacent underlying raised structures | Composite spacer scheme with low overlapped parasitic capacitance | Composite spacer scheme with low overlapped parasitic capacitance | Process for wafer edge profile control using gas flow control ring | Process and Apparatus for Wafer Edge Profile Control Using Gas Flow Control Ring | Process and Apparatus for Wafer Edge Profile Control Using Gas Flow Control Ring | Adaptive off tester screening method based on intrinsic die parametric measurements | Inter-layer interconnection structure for large electrical connections | Inter-layer interconnection structure for large electrical connections | Linear capacitor and process for making same | Linear capacitor and process for making same | Optical error minimization in a semiconductor manufacturing apparatus | Optical error minimization in a semiconductor manufacturing apparatus | Optical error minimization in a semiconductor manufacturing apparatus | Method of forming a low k polymer E-beam printable mechanical support | Title |

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| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
| | | | | | | Method of fabricating an integral capacitor and gate transistor having nitride and oxide polish stop layers using chemical mechanical polishing |
| 10733034 | 7148146 | 2003-12-11 | 2006-12-12 | Granted | United States of America | elimination |
| 10013572 | 6614093 | 2001-12-11 | 2003-09-02 | Granted | United States of America | Integrated inductor in semiconductor manufacturing |
| 10463158 | | 2003-06-16 | | Abandoned | United States of America | Integrated Inductor in Semiconductor Manufacturing |
| 60292832 | | 2001-05-21 | | Expired | United States of America | Web-Bases Interface With Defect Database To View And Update Failure Events |
| 10178537 | 0.5322.9 | 56-700-6006 | 2007-08-10 | Grantod | United States of America | Web-based interface with defect database to view and update failure events |
| | | | | | | Method And Structure For Forming Dielectric Layers Having Reduced |
| 10845716 | | 2004-05-14 | | Abandoned | United States of America | Dielectric Constants |
| | | | | | Inited States of America | Method and structure for forming dielectric layers having reduced |
| 1000001 | 6/7731/ | 2002-00-23 | 2004-06-10 | Granted | United States of America | Diamond barrier laver |
| 10238073 | 6734560 | 2002-09-09 | 2004-05-11 | | United States of America | Diamond barrier layer |
| 10035501 | 6743474 | 2001-10-25 | 2004-06-01 | | United States of America | Method for growing thin films |
| 10804980 | 7081296 | 2004-03-16 | 2006-07-25 | Lapsed | United States of America | Method for growing thin films |
| 11906196 | 8631547 | 2007-10-01 | 2014-01-21 | Granted | United States of America | Method Of Isolation For Acoustic Resonator Devices |
| 09497993 | 7296329 | 2000-02-04 | 2007-11-20 | Granted | United States of America | Method Of Isolation For Acoustic Resonator Devices |
| 12243137 | 7713811 | 2008-10-01 | 2010-05-11 | Lapsed | United States of America | Multiple Doping Level Bipolar Junctions Transistors And Method For Forming |
| 12727304 | 7910425 | 2010-03-19 | 2011-03-22 | Granted | United States of America | Multiple Doping Level Bipolar Junctions Transistors And Method For Forming |
| 10953894 | 7095094 | 2004-09-29 | 2006-08-22 | Lapsed | United States of America | Multiple Doping Level Bipolar Junctions Transistors And Method For Forming |
| 13026528 | 8143120 | 2011-02-14 | 2012-03-27 | Granted | United States of America | Multiple Doping Level Bipolar Junctions Transistors And Method For Forming |
| 11458270 | 7449388 | 2006-07-18 | 2008-11-11 | Lapsed | United States of America | Method For Forming Multiple Doping Level Bipolar Junctions Transistors |
| 10955238 | 7345364 | 2004-09-30 | 2008-03-18 | Granted | United States of America | Structure And Method For Improved Heat Conduction For Semiconductor Devices |
| | ,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,, | | -0 -0 000 | | I bitad States of Amorica | Structure And Method For Improved Heat Conduction For Semiconductor |
| 10773900 | 7078280 | 2004-02-06 | 2006-07-18 | Lapsed | United States of America | Vertical Replacement-Gate Silicon-On-Insulator Transistor |
| 11419356 | 7259048 | 2006-05-19 | 2007-08-21 | Granted | United States of America | Vertical Replacement-Gate Silicon-On-Insulator Transistor |
| | | | | - | | Vertical Replacement-Gate (VRG) Silicon-On-Insulator (SOI) CMOS |
| 09968388 | 0,0000 | 2001-09-28 | 2007 03 23 | Abandoned | United States of America | Lithographically Defined CMOS Threshold Voltage |
| | | | | L | | |

| Method And System Of Using Offset Gag For CMP Polishing Pad Alignment And Adjustment | United States of America | Granted | 2008-03-04 | 2004-09-29 | 7338569 | 10953477 |
|---|--------------------------|---------|------------|------------|----------|----------|
| Metal-Oxide-Semiconductor Device Having Trenched Diffusion Region And Method Of Forming Same | United States of America | Lapsed | 2014-02-11 | 2012-03-23 | 8648445 | 13428540 |
| Metal-Oxide-Semiconductor Device Having Trenched Diffusion Region And Method Of Forming Same | United States of America | Granted | 2012-04-10 | 2007-12-04 | 8153484 | 11999168 |
| Mold For Non-Photolithographic Fabrication Of Microstructures | United States of America | Granted | 2001-11-27 | 1999-09-09 | 6322736 | 09393032 |
| Mold For Non-Photolithographic Fabrication Of Microstructures | United States of America | Granted | 2000-03-07 | 1998-03-27 | 6033202 | 09049531 |
| Alignment Techniques For Photolithography | United States of America | Granted | 2000-03-28 | 1998-07-08 | 6042975 | 09111534 |
| Method Of Manufacturing Schottky Gate Transistor Utilizing Alignment Techniques With Multiple Photoresist Layers | United States of America | Granted | 2000-10-31 | 2000-03-10 | 6139995 | 09523210 |
| Integrated Circuit Having Amorphous Silicide Layer In Contacts And Vias AndMethod Of Manufacture Therefor | United States of America | Expired | 1999-01-12 | 1997-03-12 | 5858873 | 08816185 |
| Integrated Circuit Having Amorphous Silicide Layer In Contacts And Method Of Manufacture Therefor | United States of America | Expired | 2000-02-22 | 1998-05-06 | 6028359 | 09073556 |
| Semiconductor Device Having Aluminum Contacts Or Vias And Method Of Manufacture Therefor | United States of America | Expired | 2000-12-05 | 1998-10-05 | 6157082 | 09166832 |
| Semiconductor Device Having Aluminum Contacts Or Vias And Method Of Manufacture Therefor | United States of America | Expired | 1999-06-15 | 1997-03-18 | 5913146 | 08820063 |
| Method For Making An Interconnect Layer And A Semiconductor Device Including The Same | United States of America | Granted | 2002-08-20 | 2000-01-18 | 6436807 | 09484310 |
| Semiconductor Device Having An Interconnect Layer With A Plurality Of Layout Regions Having Substantially Uniform Densities Of Active Interconnects And Dummy Fills | United States of America | Granted | 2004-01-27 | 2002-05-16 | 6683382 | 10147384 |
| Integrated Circuit Early Life Failure Detection By Monitoring Changes In Current Signatures | United States of America | Granted | 2004-03-30 | 2000-04-25 | 6714032 | 09558130 |
| Integrated Circuit Early Life Failure Detection By Monitoring Changes In Current Signatures | United States of America | Granted | 2005-03-29 | 2004-02-12 | 6873171 | 10777250 |
| Electrostatic Discharge Protection In Double Diffused MOS Transistors | United States of America | Granted | 2003-06-10 | 2001-06-29 | 6576506 | 09896669 |
| Electrostatic Discharge Protection In Double Diffused MOS Transistors | United States of America | Lapsed | 2004-11-23 | 2003-04-08 | 6821831 | 10409423 |
| Multiple Operating Voltage Vertical Replacement-Gate (VRG) Transistor | United States of America | Lapsed | 2006-06-06 | 2003-10-14 | 7056783 | 10684713 |
| Multiple Operating Voltage Vertical Replacement-Gate (VRG) Transistor | United States of America | Granted | 2004-02-03 | 2001-09-21 | 6686604 | 09961477 |
| Method Of Ion Implantation For Achieving Desired Dopant Concentration | United States of America | Granted | 2006-05-23 | 2003-07-14 | 7049199 | 10619058 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|----------|----------|------------|------------|-----------|--------------------------|--|
| 11968930 | 7527544 | 2008-01-03 | 2009-05-05 | Lapsed | United States of America | System Of Using Offset Gage For CMP Polishing Pad Alignment And Adjustment |
| 09150529 | 6215158 | 1998-09-10 | 2001-04-10 | Granted | United States of America | Device And Method For Forming Semiconductor Interconnections In An Integrated Circuit Substrate |
| 09631546 | 6503787 | 2000-08-03 | 70-10-8002 | Granted | United States of America | Device And Method For Forming Semiconductor Interconnections In An Integrated Circuit Substrate |
| 11641507 | 7537984 | 2006-12-19 | 2009-05-26 | Lapsed | United States of America | III-V Power Field Effect Transistors |
| 10948897 | 7180103 | 2004-09-24 | 2007-02-20 | Granted | United States of America | III/V Power Field Effect Transistors |
| 10926631 | 7109589 | 2004-08-26 | 2006-09-19 | Granted | United States of America | Integrated Circuit With Substantially Perpendicular Wire Bonds |
| 11494221 | 7465655 | 2006-07-27 | 2008-12-16 | Granted | United States of America | Integrated Circuit With Substantially Perpendicular Wire Bonds |
| 08752235 | 5811916 | 1996-11-19 | 1998-09-22 | Expired | United States of America | Field Emission Devices Employing Enhanced Diamond Field Emitters |
| 08752234 | 5744195 | 1996-11-19 | 1998-04-28 | Expired | United States of America | Field Emission Devices Employing Enhanced Diamond Field Emitters |
| 08331458 | 5637950 | 1994-10-31 | 1997-06-10 | Expired | United States of America | Field Emission Devices Employing Enhanced Diamond Field Emitters |
| 10850812 | 7235489 | 2004-05-21 | 2007-06-26 | Granted | United States of America | Device And Method To Eliminate Shorting Induced By Via To Metal Misalignment |
| 11738050 | 7675179 | 2007-04-20 | 60-20-0107 | Lapsed | United States of America | Device And Method To Eliminate Shorting Induced By Via To Metal Misalignment |
| 09246402 | 6214675 | 1999-02-08 | 2001-04-10 | | United States of America | A Method For Fabricating A Merged Integrated Circuit Device |
| 09789254 | 6627963 | 2001-02-20 | 08-60-8002 | Granted | United States of America | Method For Fabricating A Merged Integrated Circuit Device |
| 10300254 | 6762457 | 2002-11-20 | 2004-07-13 | Granted | United States of America | LDMOS Device Having A Tapered Oxide |
| 09641086 | 6506641 | 2000-08-17 | 2003-01-14 | Granted | United States of America | The Use Of Selective Oxidation To Improve LDMOS Power Transistors |
| 11419252 | 7381607 | 2006-05-19 | 2008-06-03 | Granted | United States of America | A Method Of Forming A Spiral Inductor In A Semiconductor Substrate |
| 10646997 | 7075167 | 2003-08-22 | 2006-07-11 | Lapsed | United States of America | A Spiral Inductor Formed In A Semiconductor Substrate And A Method For Forming The Inductor |
| 09335646 | | 1999-06-18 | | Abandoned | United States of America | A CMOS Integrated Circuit Having Vertical Transistors And A Process For Fabricating Same |
| 10211674 | 6653181 | 2002-08-02 | 2003-11-25 | Granted | United States of America | A CMOS Integrated Circuit Having Vertical Transistors And A Process For Fabricating Same |
| 10918981 | 7345354 | 2004-08-16 | 2008-03-18 | Granted | United States of America | Increased Quality Factor Of A Varactor In An Integrated Circuit Via A High Conductive Region In A Well |
| 10454133 | 6825089 | 2003-06-04 | 2004-11-30 | Granted | United States of America | Increased Quality Factor Of A Varactor In An Integrated Circuit Via A High Conductive Region In A Well |
| 09652479 | 6373087 | 2000-08-31 | 2002-04-16 | Granted | United States of America | Methods of Fabricating A Metal-Oxide-Metal Capacitor And Associated Apparatus |
| 10080186 | 6730601 | 2002-02-21 | 2004-05-04 | Granted | United States of America | Methods of Fabricating A Metal-Oxide-Metal Capacitor |

| Method For Making An Integrated Circuit Device Including A Graded, Grown, High Quality Gate Oxide Layer And A Gate Electrode Layer With Improved Dopant Activation | United States of America | Abandoned | | 2000-08-30 | | 09651593 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| Method For Making An Integrated Circuit Device Including A Graded, Grown, High Quality Gate Oxide Layer And A Nitride Layer | United States of America | Granted | 2003-12-30 | 2000-08-30 | 6670242 | 09651447 |
| Method For Making Field Effect Devices And Capacitors With Improved Thin Film Dielectrics And Resulting Devices | United States of America | Granted | 1999-12-14 | 1998-04-15 | 6001741 | 09060420 |
| Method For Making Field Effect Devices And Capacitors With Thin Film Dielectrics And Resulting Devices | United States of America | Granted | 2001-09-04 | 1999-11-04 | 6284663 | 09434424 |
| Method for Removing Etching Residues and Contaminants | United States of America | Granted | 2000-04-04 | 1998-10-01 | 6046115 | 09164283 |
| Method For Removing Etching Residues And Contaminants | United States of America | Granted | 1998-12-15 | 1997-11-26 | 5849639 | 08979297 |
| Method Of Electrical Testing | United States of America | Granted | 2006-11-07 | 2005-05-26 | 7132840 | 11138152 |
| Method Of Electrical Testing Of An Integrated Circuit With An Electrical Probe | United States of America | Granted | 2007-07-03 | 2006-09-29 | 7239160 | 11540056 |
| High\{miDensity Inter\{miDie Interconnect Structure | United States of America | Granted | 2006-05-16 | 2003-08-08 | 7045835 | 10638248 |
| High\(miDensity Inter\(miDie Interconnect Structure | United States of America | Abandoned | | 2006-03-29 | | 11392375 |
| Method of coupling capacitance reduction | United States of America | Granted | 2002-08-13 | 2001-07-16 | 6432812 | 09906331 |
| Coupling Capacitance Reduction | United States of America | Abandoned | | 2002-06-14 | | 10171701 |
| Method Of Making A Graded Grown, High Quality Oxide Layer For A Semiconductor Device | United States of America | Granted | 2003-04-01 | 2000-01-11 | 6541394 | 09481992 |
| Planar Surfaces | United States of America | Granted | 2007-01-30 | 2004-11-12 | 7169714 | 10986984 |
| Mothod And Structure For Graded Gate Oxides On Vertical And Non | | | | | | |
| A Graded Grown Gate Oxide (G3) For A Vertical Replacement Gate (VRG) MOSFET. | United States of America | Abandoned | | 2002-06-25 | | 10179057 |
| An Electronic Component For An Integrated Circuit | United States of America | Expired | 1998-10-20 | 1997-05-27 | 5825073 | 08863713 |
| A Device and Method of Forming A Metal To Metal Capacitor Within an Integrated Circuit | United States of America | Expired | 2000-03-21 | 1997-08-12 | 6040616 | 08909563 |
| Integrated Circuit Capacitor | United States of America | Expired | 1997-08-05 | 1995-06-06 | 5654581 | 08472033 |
| Method For Making A Capacitor | United States of America | Expired | 1998-12-22 | 1996-05-09 | 5851870 | 08644086 |
| Method for Making A Metal to metal Capacitor | United States of America | Expired | 1996-11-19 | 1994-12-09 | 5576240 | 08353015 |
| Integrated Circuits | United States of America | Granted | 2004-04-27 | 2002-01-18 | 6728940 | 10053097 |
| Apparatus And Method For Determining Process Width Variations In Integrated Circuits | United States of America | Granted | 2002-04-16 | 2000-03-31 | 6373266 | 09540473 |
| Metal-Oxide-Semiconductor Device Including A Buried Lightly-Doped Drain Region | United States of America | Lapsed | 2005-08-09 | 2003-09-30 | 6927453 | 10675633 |
| Metal\{miOxide\{miSemiconductor Device Including A Buried Lightly\{miDoped Drain Region | United States of America | Granted | 2007-11-20 | 2005-04-28 | 7297606 | 11116903 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method And Apparatus For Using Across Wafer Back Pressure Differentials To Influence The Performance Of Chemical Mechanical Polishing | United States of America | Abandoned | | 1998-01-09 | | 09005364 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Method and apparatus for using across wafer back pressure differentials to influence the performance of chemical mechanical polishing | United States of America | Granted | 2001-01-30 | 1999-11-16 | 6179956 | 09442078 |
| Interconnect-embedded metal-insulator-metal capacitor | United States of America | Granted | 2003-01-07 | 2000-02-02 | 6504202 | 09496971 |
| Method of forming a metal-insulator-metal capacitor in an interconnect cavity | United States of America | Lapsed | 2006-10-10 | 2002-09-27 | 7118985 | 10260824 |
| Method of reducing silicon oxynitride gate insulator thickness in some transistors of a hybrid integrated circuit to obtain increased differential in gate insulator thickness with other transistors of the hybrid circuit | United States of America | Lapsed | 2003-12-02 | 2002-11-26 | 6656805 | 10304631 |
| Method of reducing silicon oxynitride gate insulator thickness in some transistors of a hybrid integrated circuit to obtain increased differential in gate insulator thickness with other transistors of the hybrid circuit | United States of America | Granted | 2003-02-18 | 2000-11-28 | 6521549 | 09724225 |
| Integrated circuit having low voltage and high voltage devices on a common semiconductor substrate | United States of America | Granted | 2001-02-27 | 2000-02-01 | 6194766 | 09495512 |
| Formation of high-voltage and low-voltage devices on a semiconductor substrate | United States of America | Granted | 2000-10-17 | 1998-01-13 | 6133077 | 09006918 |
| Residual Oxygen Reduction System | United States of America | Abandoned | | 2003-08-13 | | 10640530 |
| Residual oxygen reduction system | United States of America | Granted | 2003-10-21 | 2000-08-29 | 6635116 | 09650164 |
| Process For Controlling Dopant Diffusion In A Semiconductor Layer And Semiconductor Layer Formed Thereby | United States of America | Expired | 1998-03-24 | 1997-05-23 | 5731626 | 08862226 |
| A Semiconductor Device Configured to Control Dopant Diffusion In the Semiconductor Device Substrate | United States of America | Expired | 2000-11-28 | 1998-01-30 | 6153920 | 09015981 |
| Method For Making An Integrated Circuit Device Including A Graded, Grown, High Quality Gate Oxide Layer | United States of America | Abandoned | | 2000-08-30 | | 09651451 |
| Method For Making A High Quality, Graded, Grown Gate Oxide Layer Including Native Oxide Removal | United States of America | Abandoned | | 2000-08-30 | | 09651450 |
| Integrated Circuit Device Including a Graded, Grown, High Quality Gate Oxide Layer And a Nitride Layer | United States of America | Abandoned | | 2000-08-30 | | 09651458 |
| Flash Device w\(slG3 (High Temperature) Oxide Grown In FTP or RTP Furnace | United States of America | Abandoned | | 2000-08-30 | | 09651592 |
| Integrated Circuit Device Including a Graded, Grown, High Quality Gate Oxide Layer | United States of America | Abandoned | | 2000-08-30 | | 09651857 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 1995-06-06 1997-01-06 1999-09-14 1999-09-14 2001-09-14 1998-04-30 1995-09-26 1999-02-05 | 1998-05-19 1995-06-06 1997-01-06 1999-09-14 1998-04-30 1998-04-30 1995-09-26 | 1996-12-17 1998-05-19 1995-06-06 1997-01-06 1999-09-14 1999-09-14 1998-04-30 1995-09-26 | 1998-12-15 1996-12-17 1998-05-19 1995-06-06 1997-01-06 1999-09-14 1998-04-30 1995-09-26 1999-02-05 | 2000-05-31 1998-12-15 1996-12-17 1998-05-19 1998-05-19 1997-01-06 1997-01-06 1999-09-14 1998-04-30 1995-09-26 1999-02-05 | 1999-10-22 2000-05-31 1998-12-15 1998-05-19 1998-05-19 1999-09-14 1999-09-14 1998-04-30 1999-02-05 1999-02-05 |
|--|--|--|--|--|--|
| 1995-06-06 1997-01-06 1998-04-07 1999-09-14 2001-12-11 2001-09-14 2004-09-21 2001-09-14 2004-09-21 1998-04-30 1999-07-06 1995-09-26 1998-12-01 1999-02-05 2000-05-16 | | | | | |
| 1998-04-07 2001-12-11 2004-09-21 1999-07-06 1998-12-01 | 2000-10-10 1998-04-07 1998-12-11 2001-12-11 2004-09-21 1999-07-06 1998-12-01 | 1998-10-13 2000-10-10 1998-04-07 2001-12-11 2004-09-21 1999-07-06 1998-12-01 | 2000-09-12 1998-10-13 2000-10-10 1998-04-07 1998-04-07 2001-12-11 2004-09-21 1999-07-06 1998-12-01 | 2002-05-07 2000-09-12 1998-10-13 1998-10-10 2000-10-10 1998-04-07 2001-12-11 2004-09-21 1999-07-06 1998-12-01 | 2002-07-23 2002-05-07 2000-09-12 2000-10-13 1998-10-13 2000-10-10 1998-04-07 1998-04-07 1999-07-06 1998-12-01 |
| 1998-04-07 2001-12-11 2004-09-21 1999-07-06 | 2000-10-10 1998-04-07 2001-12-11 2004-09-21 1999-07-06 | 1998-10-13 2000-10-10 1998-04-07 2001-12-11 2004-09-21 1999-07-06 | 2000-09-12 1998-10-13 2000-10-10 1998-04-07 1998-04-07 2001-12-11 2004-09-21 1999-07-06 | 2002-05-07 2000-09-12 1998-10-13 1998-10-10 2000-10-10 1998-04-07 2001-12-11 2004-09-21 1999-07-06 | 2002-07-23 2002-05-07 2000-09-12 2000-10-13 2000-10-10 1998-04-07 1998-04-07 2001-12-11 2004-09-21 1999-07-06 |
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| Abandoned | 2000-10-10 Expired Abandoned | 1998-10-13 Expired 2000-10-10 Expired Abandoned | 2000-09-12 Granted 1998-10-13 Expired 2000-10-10 Expired Abandoned | 2002-05-07 Granted 2000-09-12 Granted 1998-10-13 Expired 2000-10-10 Expired Abandoned | 2002-07-23 Granted 2002-05-07 Granted 2000-09-12 Granted 1998-10-13 Expired 2000-10-10 Expired Abandoned |
| | 2000-10-10 Expired | 1998-10-13 Expired 2000-10-10 Expired | 2000-09-12 Granted 1998-10-13 Expired 2000-10-10 Expired | 2002-05-07 Granted 2000-09-12 Granted 1998-10-13 Expired 2000-10-10 Expired | 2002-07-23 Granted 2002-05-07 Granted 2000-09-12 Granted 1998-10-13 Expired 2000-10-10 Expired |

| 1998287829 4555410 | 09064802 6418353 | 10094520 6654226 | 09231265 6335295 | 2000008156 4777494 | 08823305 6211096 | 08832245 5780329 | 12689749 8030199 | 10224220 | 12114589 | 08587061 6498080 | 08430084 5891784 | 1020117008762 10-13 | 13119005 8610215 | 098130968 1413235 | 14073526 | 2008801316818 ZL200 | 13443691 | 12947948 8289051 | 09896363 6812134 | 11418873 7393780 | 10893659 7071094 | 09884805 6852243 | Appino Patentino |
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| | | | | | | | | N | 2 | | | 10-1306685 | | | | ZL200880131681.8 2 | 2 | | | | | | |
| 1998-10-09 | 1998-04-22 | 2002-03-08 | 1999-01-15 | 2000-01-17 | 1997-03-21 | 1997-04-03 | 2010-01-19 | 2002-08-20 | 2008-05-02 | 1996-01-16 | 1995-04-27 | 2008-09-19 | 2011-03-15 | 2009-09-14 | 2013-11-06 | 2008-09-19 | 2012-04-10 | 2010-11-17 | 2001-06-28 | 2006-05-04 | 2004-07-16 | 2001-06-18 | HiedDate |
| 2010-07-23 | 2002-07-09 | 2003-11-25 | 2002-01-01 | 2011-07-08 | 2001-04-03 | 1998-07-14 | 2011-10-04 | | | 2002-12-24 | 1999-04-06 | 2013-09-04 | 2013-12-17 | 2013-10-21 | | 2013-06-19 | | 2012-10-16 | 2004-11-02 | 2008-07-01 | 2006-07-04 | 2005-02-08 | GrantDate |
| Lapsed | Granted | Lapsed | Granted | Granted | Expired | Expired | Granted | Abandoned | Abandoned | Expired | Expired | Lapsed | Granted | Lapsed | Abandoned | Lapsed | Abandoned | Lapsed | Granted | Granted | Granted | Lapsed | Shieic |
| Japan | United States of America | United States of America | United States of America | Japan | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Korea, Republic of (KR) | United States of America | Taiwan | United States of America | China | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Country |
| Apparatus And A Method For Forming An Oxide Film On A Semiconductor | Automating photolithography in the fabrication of integrated circuits | Thermal low k dielectrics | Flame-free wet oxidation | Pyrogenic Devoid Wet Oxidation | Tunable dielectric constant oxide and method of manufacture | Process for fabricating a moderate-depth diffused emitter bipolar transistor in a BICMOS device without using an additional mask | Transistor Fabrication Method | Allotropic Or Morphologic Change In Silicon Induced By Electromagnetic Radiation For Resistance Tuning Of Integrated Circuits | Allotropic Or Morphologic Change In Silicon Induced By Electromagnetic Radiation For Resistance Tuning Of Integrated Circuits | Allotropic Or Morphologic Change In Silicon Induced By Electromagnetic Radiation For Resistance Tuning Of Integrated Circuits | Allotropic Or Morphologic Change In Silicon Induced By Electromagnetic Radiation For Resistance Tuning Of Integrated Circuits | Allotropic Or Morphologic Change In Silicon Induced By Electromagnetic Radiation For Resistance Tuning Of Integrated Circuits | Input/Output Core Design and Method of Manufacture Therefor | Input/Output Core Design and Method of Manufacture Therefor | Dual layer barrier film techniques to prevent resist poisoning | Dual layer barrier film techniques to prevent resist poisoning | Dual layer barrier film techniques to prevent resist poisoning | Confinement device for use in dry etching of substrate surface and method of dry etching a wafer surface | T C C C C C C C C C C C C C C C C C C C |

| Purging Gas Control Structure For Cvd Chamber | United States of America | Abandoned | | 1997-11-26 | | 08979733 |
|--|--------------------------|-----------|------------|------------|----------|------------|
| | United States of America | Granted | 2001-12-18 | 1998-05-11 | 6331468 | 09076399 |
| Structure and method for measuring interface resistance in multiple interface contacts and via structures in semiconductor devices | United States of America | Granted | 2000-01-11 | 1998-03-20 | 6013952 | 09046113 |
| Method For Artificially-Inducing Reverse Short-Channel Effects In Deep Sub-Micron Cmos Devices | Korea, Republic of (KR) | Lapsed | 2000-08-21 | 1997-11-25 | 0271949 | 9762865 |
| Inductor with cobalt/nickel core for integrated circuit structure with high inductance and high Q-factor | United States of America | Granted | 2000-12-26 | 1998-05-13 | 6166422 | 09079413 |
| Test circuitry for determining the defect density of a semiconductor process as a function of individual metal layers | United States of America | Granted | 2000-05-09 | 1998-04-21 | 6061814 | 09063801 |
| Metal-encapsulated polysilicon gate and interconnect | United States of America | Granted | 2000-03-14 | 1998-04-27 | 6037233 | 09069027 |
| Apparatus for externally monitoring RPM of spin rinse dryer | United States of America | Granted | 2000-06-13 | 1998-05-19 | 6073361 | 09081337 |
| Method And Apparatus For Eliminating Peeling At End Edge Of Semiconductor Substrate In Metal Organic Chemical Vapor Deposition Of Titanium Nitrite | Japan | Lapsed | 2011-12-09 | 1998-03-04 | 4881497 | 1998051650 |
| Process For Forming Improved Cobalt Silicide Layer On Integrated Circuit Structure Using Two Capping Layers. | Japan | Lapsed | 2012-05-18 | 1998-04-07 | 4996781 | 1998094757 |
| Insulated-Gate Field-Effect Transistors Having Different Gate Capacitances | Japan | Lapsed | 2009-10-02 | 1998-01-27 | 4381491 | 10014449 |
| Silicon carbide CMOS channel | United States of America | Granted | 2002-03-19 | 2001-06-29 | 6358806 | 09896958 |
| Insulated-Gate Field-Effect Transistors Having Different Gate Capacitances | Taiwan | Lapsed | 2001-06-07 | 1998-03-04 | 135215 | 87103103 |
| Process for forming vias, and trenches for metal lines, in multiple dielectric layers of integrated circuit structure | United States of America | Granted | 2000-03-14 | 1998-06-15 | 6037262 | 09098032 |
| Parametric device signature | United States of America | Granted | 2003-07-29 | 2001-08-02 | 6601008 | 09920890 |
| Modified multilayered metal line structure for use with tungsten-filled vias in integrated circuit structures | United States of America | Granted | 2000-11-14 | 1998-06-15 | 6147409 | 09098019 |
| Method For Artificially-Inducing Reverse Short-Channel Efforts In Deep Sub-Micron Cmos Devices | Taiwan | Lapsed | 2000-05-11 | 1998-02-25 | 115428 | 87102678 |
| Pre-Conditioning Polishing Pads For Chemical-Mechanical Polishing | Japan | Lapsed | 2010-08-13 | 1998-04-08 | 4565674 | 1998096236 |
| Dual nitrogen implantation techniques for oxynitride formation in semiconductor devices | United States of America | Granted | 2001-11-27 | 1999-12-29 | 6323106 | 09474666 |
| litle | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Process for forming improved cobalt silicide layer on integrated circuit structure using two capping layers | United States of America | Expired | 1999-05-11 | 1997-04-07 | 5902129 | 08833597 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Method of making a barrier layer for via or contact opening of integrated circuit structure | United States of America | Expired | 1998-06-23 | 1996-12-05 | 5770520 | 08760466 |
| On the use of non-spherical carriers for substrate chemi-mechanical polishing | United States of America | Expired | 1998-06-23 | 1996-12-23 | 5769692 | 08772310 |
| Method and apparatus for using pressure differentials through a polishing pad to improve performance in chemical mechanical polishing | United States of America | Expired | 1999-08-03 | 1997-08-25 | 5931719 | 08918846 |
| Use of abrasive tape conveying assemblies for conditioning polishing pads | United States of America | Expired | 1999-08-31 | 1997-10-02 | 5944585 | 08942991 |
| Method of manufacturing semiconductor device | United States of America | Expired | 1997-05-06 | 1994-12-07 | 5627099 | 08351516 |
| Etch process selective to cobalt silicide for formation of integrated circuit structures | United States of America | Expired | 1999-08-03 | 1997-06-23 | 5933757 | 08879659 |
| Chemical mechanical polishing pad slurry distribution grooves | United States of America | Expired | 1999-03-16 | 1997-08-19 | 5882251 | 08914854 |
| Process for forming integrated circuit structure with metal silicide contacts using notched sidewall spacer on gate electrode | United States of America | Expired | 1998-12-22 | 1997-08-28 | 5851890 | 08919394 |
| Method of forming thin polygates for sub quarter micron CMOS process | United States of America | Granted | 2000-12-19 | 1997-12-16 | 6162714 | 08991397 |
| Process for forming photoresist mask over integrated circuit structures with critical dimension control | United States of America | Expired | 1999-05-11 | 1997-07-02 | 5902704 | 08887910 |
| Apparatus and method for polish removing a precise amount of material from a wafer | United States of America | Expired | 1999-02-02 | 1997-08-20 | 5865666 | 08915000 |
| Process for abrasive removal of copper from the back surface of a silicon substrate | United States of America | Granted | 2000-05-09 | 1997-12-15 | 6059637 | 08990315 |
| Method and apparatus for removing residual material from an alignment mark of a semiconductor wafer | United States of America | Granted | 2001-09-11 | 1998-12-11 | 6288773 | 09210184 |
| Composite semiconductor gate dielectrics | United States of America | Granted | 2000-07-11 | 1998-03-09 | 6087229 | 09037588 |
| Method for removing particles from a semiconductor wafer | United States of America | Granted | 2001-06-19 | 1998-09-09 | 6248180 | 09150220 |
| Apparatus and process for deposition of thin film on semiconductor substrate while inhibiting particle formation and deposition | United States of America | Granted | 2000-10-03 | 1998-05-11 | 6127286 | 09076502 |
| Process for selective polishing of metal-filled trenches of integrated circuit structures | United States of America | Granted | 2003-01-07 | 2001-06-14 | 6503828 | 09882124 |
| Integrated Circuit Structure With Thin Dielectric Between At Least Local Interconnect Level And First Metal Interconnect Level, And Process For Making Same | United States of America | Abandoned | | 1998-05-18 | | 09081403 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 10949760 73 | 09426061 67 | 10984286 71 | 11012003 73 | 10953322 75 | 10945777 73 | 10973851 72 | 09405805 62 | 200864008 | 2012122801 57 | 013033220 60 | 989197264 69 | 09777996 67 | 11524107 74 | 2000322452 | 08475028 56 | 08586587 63 | 08592870 59 | 08730809 57 |
|---------------------------|---|---|--|---------------------------------------|--|---|--|--|--|-------------------------------|---|-------------------------------|--|---|--|---|--|---|
| 7315360 | 6756674 | 7148556 | 7372547 | 7550236 | 7300869 | 7204920 | 6225215 | | 5744790 | 60145418.9 | 69831734.3 | 6724404 | 7408227 | 3527700 | 5661069 | 6303995 | 5953631 | 5717490 |
| 2004-09-24 | 1999-10-22 | 2004-11-09 | 2004-12-14 | 2004-09-29 | 2004-09-20 | 2004-10-25 | 1999-09-24 | 2000-05-10 | 2012-05-30 | 2001-04-09 | 1998-04-02 | 2001-02-06 | 2006-09-20 | 2000-10-23 | 1995-06-06 | 1996-01-11 | 1996-01-24 | 1996-10-17 |
| 2008-01-01 | 2004-06-29 | 2006-12-12 | 2008-05-13 | 2009-06-23 | 2007-11-27 | 2007-04-17 | 2001-05-01 | | 2015-05-15 | 2011-10-05 | 2005-09-28 | 2004-04-20 | 2008-08-05 | 2004-02-27 | 1997-08-26 | 2001-10-16 | 1999-09-14 | 1998-02-10 |
| Granted | Granted | Granted | Granted | Lapsed | Granted | Granted | Granted | Abandoned | Granted | Lapsed | Granted | Granted | Granted | Lapsed | Expired | Expired | Expired | Expired |
| United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Japan | Japan | Germany (Federal Republic of) | Germany (Federal Republic of) | United States of America | United States of America | Japan | United States of America | United States of America | United States of America | United States of America |
| Surface coordinate system | Low dielectric constant silicon oxide-based dielectric layer for integrated circuit structures having improved compatibility with via filler materials, and method of making same | High performance diode-implanted voltage-controlled poly resistors for mixed-signal and RF applications | Process and apparatus for achieving single exposure pattern transfer using maskless optical direct write lithography | MULTI WAVELENGTH MULTI LAYER PRINTING | Integrated barrier and seed layer for copper interconnect technology | Contact ring design for reducing bubble and electrolyte effects during electrochemical plating in manufacturing | Method for enhancing anti-reflective coatings used in photolithography of electronic devices | Damascene Capacitors For Integrated Circuits | Damascene Capacitors For Integrated Circuits | Copper ICs Interconnect | Process for Fabricating a Moderate-Depth Diffused Emitter Bipolar Transistor in a BICMOS Device Without Using an Additional Mask | Cluster tool reporting system | Apparatus and method of manufacture for integrated circuit and CMOS device including epitaxially grown dielectric on silicon carbide | Low Dielectric Constant Silicon Oxide-Based Dielectric Layer for Integrated Circuit Structures Having Improved Compatibility with Via Filler Materials, and Method of Making Same | Method of forming an MOS-type integrated circuit structure with a diode formed in the substrate under a polysilicon gate electrode to conserve space | Sidewall structure for metal interconnect and method of making same | Low stress, highly conformal CVD metal thin film | Method for identifying order skipping in spectroreflective film measurement equipment |

| Damascene Capacitors For Integrated Circuits | United States of America | Granted | 2004-06-15 | 1999-05-12 | 6750495 | 09310388 |
|--|--------------------------|---------|------------|------------|-----------|---------------|
| device including epitaxially grown dielectric on silicon carbide | United States of America | Granted | 2006-11-21 | 2003-09-10 | 7138292 | 10659134 |
| Apparatus and method of manufacture for integrated circuit and CMOS | | | | | | |
| Split-Gate Metal-Oxide-Semiconductor Device | United States of America | Granted | 2004-03-23 | 2003-05-16 | 6710416 | 10439863 |
| Device And Method Using Isotopically Enriched Silicon | United States of America | Lapsed | 2009-02-24 | 2004-06-23 | 7494888 | 10875029 |
| Overlay Metrology Using Scatterometry Profiling | United States of America | Lapsed | 2006-01-10 | 2002-05-30 | 6985229 | 10158775 |
| Method for Optimizing Wafer Edge Patterning | United States of America | Lapsed | 2014-04-01 | 2004-08-30 | 8685633 | 10929706 |
| Chemical mechanical electropolishing system | United States of America | Lapsed | 2005-08-09 | 2003-10-24 | 6927177 | 10693110 |
| Transistors | United States of America | Granted | 2004-07-06 | 2001-09-18 | 6759730 | 09956382 |
| Bipolar Junction Transistor Compatible With Vertical Replacement Gate | | | | | | |
| All integrated circuit including ESD circuits for A Mathematical Module Alla | United States of America | Granted | 2003-04-29 | 2000-08-31 | 6556409 | 09652571 |
| bimetallic oxide compositions for gate dielectrics | United States of America | Lapsed | 2006-03-21 | 2004-07-01 | /015096 | 1088313/ |
| Fabrication of metal contacts for deep-submicron technologies | United States of America | Granted | 2004-04-27 | 2001-09-28 | 6727165 | 09967074 |
| Monitoring And Control Of A Fabrication Process | Korea, Republic of (KR) | Lapsed | 2010-08-27 | 2003-02-24 | 10-979658 | 1020047013135 |
| Titanium-Tantalum Barrier Layer Film And Method For Forming The Same | United States of America | Granted | 2001-12-18 | 2000-03-06 | 6331484 | 09519193 |
| Electrochemical Abatement Of Perfluorinated Compounds | United States of America | Granted | 2002-04-23 | 1999-12-21 | 6375912 | 09469090 |
| Process For Semiconductor Device Fabrication | United States of America | Expired | 1998-09-29 | 1995-11-16 | 5814562 | 08558997 |
| Holder, System, And Process For Improving Overlay In Lithography | United States of America | Lapsed | 2005-01-25 | 2002-06-03 | 6847433 | 10159268 |
| X-Ray System | United States of America | Granted | 2003-08-12 | 2000-12-19 | 6606371 | 09745236 |
| Method For Making A Photoresist Layer Having Increased Resistance To Blistering, Peeling, Lifting, Or Reticulation | United States of America | Granted | 2001-10-23 | 2000-10-26 | 6306780 | 09698375 |
| Electrically Measured IC Wafer Masks Version Control Indicator | United States of America | Expired | | 1999-11-23 | | 60167132 |
| A Thin Film Toroidal Inductor | United States of America | Expired | | 2002-05-07 | | 60378476 |
| MOS Transistor And Method Of Manufacture | United States of America | Expired | | 1999-11-30 | | 60168036 |
| Planarization Technique For HDPCVD FSG Layer | United States of America | Expired | | 1999-01-26 | | 60117186 |
| Semiconductor Device With Increased Gate Insulator Lifetime | United States of America | Expired | | 1998-12-03 | | 60110711 |
| Multi-Layered WSi/WSiN/Poly (Optional) Resistor for Si IC's | United States of America | Expired | | 1999-01-12 | | 60115525 |
| Dark Spin Rinse/Dry | United States of America | Expired | | 1999-04-21 | | 60130378 |
| Solvent Absorption By CMP Pads And Its Relationship To Pad Chemistry | United States of America | Expired | | 1999-06-30 | | 60141657 |
| Field Emitting Device Comprising Field-Concentrating Nanoconductor Assembly And Method For Making The Same | United States of America | Expired | | 1999-07-15 | | 60144277 |
| Method and apparatus for establishing improved thermal communication between a die and a heatspreader in a semiconductor package | United States of America | Lapsed | 2006-10-10 | 2004-04-07 | 7119432 | 10820494 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
| | | İ | | | | |

| A Process For The Electroless Deposition of Metal On A Substrate | United States of America | Granted | 2003-02-25 | 1994-10-18 | 6524645 | 08324842 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Lithographic Process And Energy-Sensitive Material For Use Therein | United States of America | Expired | 1999-09-28 | 1997-08-25 | 5958654 | 08918781 |
| Article Comprising A Inin Film Transistor With Low Conductivity Organic Layer | United States of America | Expired | 1996-11-12 | 1994-12-09 | 5574291 | 08353032 |
| | United States of America | Expired | 1997-02-04 | 1994-12-08 | 5599730 | 08351977 |
| Self-Aligned Alignment Marks For Phase-Shifting Masks | United States of America | Expired | 1996-07-23 | 1995-04-10 | 5538819 | 08439040 |
| Integrated Circuit Multi-Level Interconnection Technique | United States of America | Expired | 1997-09-02 | 1995-03-30 | 5663677 | 08413527 |
| Electroplating tool for semiconductor manufacture having electric field control | United States of America | Granted | 2008-02-19 | 2003-06-02 | 7332062 | 10452360 |
| Method Of Making High-Speed Double-Heterostructure Bipolar Transistor Devices | United States of America | Expired | 1997-08-12 | 1996-07-18 | 5656515 | 08683291 |
| Method For Producing Tapered Lines | United States of America | Expired | 1997-09-23 | 1996-06-07 | 5670062 | 08664227 |
| Method and Apparatus for Planar Magnetron Sputtering | United States of America | Expired | 1995-08-15 | 1994-11-30 | 5441614 | 08346810 |
| Process for Making An X-Ray Mask | United States of America | Expired | 1997-08-12 | 1996-01-22 | 5656399 | 08589229 |
| Device Fabrication Using DUV/EUV Pattern Delineation | United States of America | Expired | 1996-04-23 | 1994-10-20 | 5510230 | 08326444 |
| Mini environment for Hazardous Process Tools | United States of America | Expired | 1996-08-27 | 1994-11-30 | 5549512 | 08346806 |
| Calcium Niobate And Calcium Tantalate Oxides | United States of America | Granted | 1999-11-30 | 1997-11-17 | 5993947 | 08971422 |
| Low Temperature Coefficient Dielectric Material Comprising Binary | | | | | | |
| Method of qualifying a process tool with wafer defect maps | United States of America | Granted | 2006-07-18 | 2003-09-08 | 7079966 | 10658168 |
| Integrated Circuit Devices With Isolated Circuit Elements | United States of America | Expired | 1998-06-16 | 1997-05-09 | 5767561 | 08853582 |
| Transmission | United States of America | Granted | 2001-02-27 | 1999-02-01 | 6194750 | 09243377 |
| Integrated Circuit Comprising Means For High Frequency Signal | | | | | | |
| Device And Method Of Fabricating Vias For ULSI Metallization And Interconnect | United States of America | Granted | 1999-11-30 | 1998-01-30 | 5994221 | 09016475 |
| Method and apparatus to add slurry to a polishing system | United States of America | Lapsed | 2005-12-27 | 2003-06-26 | 6979251 | 10607116 |
| System for implementing a configurable integrated circuit | United States of America | Granted | 2006-07-11 | 2004-12-17 | 7075179 | 11016014 |
| Silicon IC Contacts Using Composite TiN Barrier Layer | United States of America | Expired | 1999-10-26 | 1997-09-30 | 5972179 | 08941556 |
| Integrated Circuit Fabrication | United States of America | Expired | 2000-06-13 | 1997-09-05 | 6074933 | 08924730 |
| A Semiconductor Device Having An Anti\\miReflective Layer And A Method Of Manufacture Thereof | United States of America | Expired | 2000-10-17 | 1997-08-14 | 6133618 | 08907834 |
| Single Crystal Silicon On Polycrystalline Silicon Integrated Circuits | United States of America | Granted | 2002-05-14 | 1998-06-10 | 6388290 | 09095468 |
| Polishing Slurry | United States of America | Granted | 2000-04-11 | 1999-04-06 | 6048256 | 09286869 |
| lesting insulation Between Conductors | United States of America | Granted | 2002-07-23 | 1999-11-10 | 6424160 | 09437930 |
| Method And System For Determining Operating Staffing | United States of America | Granted | 2002-10-01 | 1999-11-12 | 6459946 | 09439048 |
| A Method Of Forming A Multi-Layered Dual-Polysilicon Structure | United States of America | Granted | 2001-02-20 | 1999-04-22 | 6191017 | 09298068 |
| Method for testing IDD at multiple voltages | United States of America | Lapsed | 2006-04-04 | 2003-11-03 | 7023230 | 10700791 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| A Device and Method of Forming A Metal To Metal Capacitor Within an Integrated Circuit | Korea, Republic of (KR) | Granted | 2000-11-10 | 1998-08-12 | 280565 | 9832710 |
|---|-------------------------------|---------|------------|------------|------------|---------------|
| System And Method Of Manufacturing Semicustom Reticles Using Reticle Primitives | Korea, Republic of (KR) | Lapsed | 2001-07-16 | 1999-06-28 | 0303937 | 19990024635 |
| Method Of Manufacturing An Integrated Circuit Using Chemical Mechanical Polishing | Korea, Republic of (KR) | Lapsed | 2005-06-08 | 1998-11-24 | 495717 | 1019980050349 |
| Capacitor Comprising Improved Taox-Based Dielectric | Korea, Republic of (KR) | Lapsed | 2005-07-25 | 1998-05-22 | 505305 | 1019980018520 |
| Method For Making An Integrated Circuit Including Alignment Marks | Korea, Republic of (KR) | Lapsed | 2007-03-19 | 2000-01-11 | 699186 | 1020000001128 |
| Process For Fabricating A Semiconductor Device Having A Metal Oxide Or A Metal Silicate GateDielectric Layer | Korea, Republic of (KR) | Lapsed | 2008-02-26 | 2001-08-17 | 809305 | 1020010049568 |
| Method For Making Field Effect Devices And Capacitors With Thin Film Dielectrics And Resulting Devices | Korea, Republic of (KR) | Lapsed | 2007-01-23 | 2000-11-01 | 675988 | 20000064498 |
| Metal-Oxide-Semiconductor Device Including A Buried Lightly-Doped Drain Region | Taiwan | Lapsed | 2010-05-21 | 2004-04-14 | 1325175 | 093110409 |
| Silicon-On-Insulator (SOI) Semiconductor Structure With Trench Including A Conductive Layer | Taiwan | Lapsed | 2007-06-01 | 2001-07-02 | 1282168 | 90116133 |
| Capacitor Comprising Improved Taox-Based Dielectric | Taiwan | Lapsed | 2001-05-16 | 1998-04-13 | NI-132141 | 87105577 |
| Integrated Circuit Capacitor And Associated Fabrication Methods | Taiwan | Lapsed | 2001-10-17 | 2000-01-06 | NI-134826 | 89100158 |
| Damascene Capacitors For Integrated Circuits | Taiwan | Granted | 2001-11-11 | 2000-03-07 | NI-144505 | 89104065 |
| A Method For Reducing Dishing Related Issues During The Formation Of Shallow Trench Isolation Structures | Taiwan | Lapsed | 2002-05-11 | 2001-06-04 | NI-157181 | 090113472 |
| Interconnections To Copper IC's | Taiwan | Lapsed | 2004-11-01 | 2001-04-09 | 1223427 | 90108450 |
| Multiple Operating Voltage Vertical Replacement-Gate (VRG) Transistor | Taiwan | Lapsed | 2004-07-07 | 2002-08-22 | NI-198062 | 91119024 |
| Method For Making Field Effect Devices And Capacitors With Thin Film Dielectrics And Resulting Devices | Taiwan | Lapsed | 2002-10-21 | 2000-11-21 | NI-165325 | 89123228 |
| blic Subsonic to Supersonic and Ultrasonic Conditioning of Polishing Pad in a Chemical Mechanical Polishing Apparatus | Germany (Federal Republic of) | Expired | 2002-01-09 | 1997-07-15 | 69709934.2 | 979319175 |
| a Modified binary search for optimizing efficiency of data collection time | United States of America | Granted | 2006-07-18 | 2003-04-14 | 7079963 | 10412867 |
| Local Area Alloying For Preventing Dishing Of Copper During Chemical Mechannical Polishing (CMP) | United States of America | Granted | 2002-10-08 | 2000-04-11 | 6461225 | 09547132 |
| a Pad conditioning monitor | United States of America | Granted | 2004-04-20 | 2003-04-25 | 6722948 | 10423096 |
| a Method For Forming Self Aligned Polysilicon Contact | United States of America | Expired | 1999-03-09 | 1991-05-30 | 5879997 | 07707365 |
| a Mechanical stress free processing method | United States of America | Granted | 2004-05-25 | 2003-04-09 | 6739953 | 10410925 |
| Semiconductor Device Having A High Voltage Termination Improvement | United States of America | Expired | 1999-09-28 | 1993-12-08 | 5959342 | 08163967 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| A Process for Fabricating Integrated Circuit Devices Having Thin Film Lapsed Japan Transistors |
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| |
| A Method For Reducing Dishing Related Issues During The Formation Of Lapsed Japan Shallow Trench Isolation Structures |
| High-Density Field Emission Elements and a Method for Forming Said Lapsed Japan Emission Elements |
| Capacitor For A Semiconductor Device And Method For Fabrication Lapsed Japan Therefor |
| Granted United States of America and to increase conductivity |
| Lapsed Japan Methods And Apparatus For Testing Integrated Circuits |
| A Device and Method of Forming A Metal To Metal Capacitor Within an Granted Japan Integrated Circuit |
| Device And Method Of Fabricating Vias For ULSI Metallization And Lapsed Japan Interconnect |
| Granted Japan Improved Wehnelt Gun For Electron Lithography |
| Silicon-On-Insulator (SOI) Semiconductor Structure With Trench Including Lapsed Japan A Conductive Layer |
| Lapsed Korea, Republic of (KR) Multiple Operating Voltage Vertical Replacement-Gate (VRG) Transistor |
| Lapsed Korea, Republic of (KR) Overlay Metrology Using Scatterometry Profiling |
| Lapsed Korea, Republic of (KR) Bipolar Junction Transistor Compatible With Vertical Replacement Gate |
| Granted Korea, Republic of (KR) Guard Ring for Improved Matching |
| High-Density Field Emission Elements and a Method for Forming Said Korea, Republic of (KR) High-Density Field Emission Elements |
| Article Comprising A Dielectric Material Of Zr-Ge-Ti-O Or Hf-Ge-Ti-O And Lapsed Korea, Republic of (KR) Method Of Making The Same |
| Local Area Alloying For Preventing Dishing Of Copper During Chemical Korea, Republic of (KR) Mechannical Polishing (CMP) |
| Granted Korea, Republic of (KR) Semiconductor Device Free Of LDD Regions |
| Lapsed Korea, Republic of (KR) Lithographic Process For Device Fabrication Using Dark-Field Illumination |
| Granted United States of America Interconnect routing using parallel lines and method of manufacture |
| Expired Korea, Republic of (KR) Method For Producing Tapered Lines |
| Status Country Title |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|-----------|------------|------------|------------|---------|----------------------------------|---|
| 09704200 | 6537923 | 2000-10-31 | 2003-03-25 | Granted | United States of America | Process for forming integrated circuit structure with low dielectric constant material between closely spaced apart metal lines |
| 983065624 | 69835260.2 | 1998-08-18 | 2006-07-19 | Lapsed | Germany (Federal Republic of) | Embedded Thin Film Passive Components |
| 003071784 | 60000174.1 | 2000-08-21 | 2002-05-22 | | Germany (Federal Republic of) | Semiconductor Device Having Regions Of Insulating Material Formed In A Semiconductor Substrate And Process Of Making The Device |
| 993071026 | 69902133.2 | 1999-09-07 | 2002-07-17 | | Germany (Federal Republic of) | Method Of Making An Article Comprising An Oxide Layer On A GaAs- Based Semiconductor Body |
| 993064708 | 69901142.6 | 1999-08-17 | 2002-04-03 | Granted | Germany (Federal Republic of) | Process For Semiconductor Device Fabrication Having Copper Interconnects |
| 973090285 | 69724972.7 | 1997-11-11 | 2003-09-17 | | Germany (Federal Republic of) | Electronic Apparatus |
| 10172849 | 6917430 | 2002-06-17 | 2005-07-12 | Lapsed | United States of America | Method to improve the control of source chemicals delivery by a carrier gas |
| 003032737 | 60032051.0 | 2000-04-18 | 2006-11-29 | | Germany (Federal Republic of) | A Method Of Forming A Multi-Layered Dual-Polysilicon Structure |
| 10078233 | 6830984 | 2002-02-15 | 2004-12-14 | Granted | United States of America | Thick traces from multiple damascene layers |
| 10033090 | 6817941 | 2001-10-25 | 2004-11-16 | Lapsed | United States of America | Uniform airflow diffuser |
| 10008170 | 6706583 | 2001-10-19 | 2004-03-16 | Granted | United States of America | High speed low noise transistor |
| 10053537 | 6673498 | 2001-11-02 | 2004-01-06 | Lapsed | United States of America | Method for reticle formation utilizing metal vaporization |
| 09970392 | 6647348 | 2001-10-03 | 2003-11-11 | Granted | United States of America | Latent defect classification system |
| 11368780 | 7476951 | 2006-03-06 | 2009-01-13 | Granted | United States of America | Selective Isotropic Etch For Titanium Based Materials |
| 08935521 | 5895960 | 1997-09-23 | 1999-04-20 | Expired | United States of America | Thin Oxide Mask Level Resistor First stage salicidation of cobalt during cobalt deposition or subsequent Ti |
| 099998/2 | 6582568 | 2001-10-19 | 2003-06-24 | | Germany (Federal Republic | Energy-Sensitive Resist Material And A Process For Device Fabrication Licina As Energy-Sensitive Posist Material Licina As Energy-Sensitive Posist Material |
| 09758603 | 6741122 | 2001-01-12 | 2004-05-25 | Granted | United States of America | Routing technique to adjust clock skew using frames and prongs |
| 08924277 | 6102962 | 1997-09-05 | 2000-08-15 | Expired | United States of America | Method for estimating quiescent current in integrated circuits |
| | | | | | | Integrated circuit structures having low k porous aluminum oxide dielectric material separating aluminum lines, and method of making |
| 09574771 | 6506678 | 2000-05-19 | 2003-01-14 | Granted | United States of America | same |
| 09817642 | 6476497 | 2001-03-26 | 2002-11-05 | Granted | United States of America | Concentric metal density power routing |
| 10271860 | 4094743 | 1998-09-25 | 2008-03-14 | Lapsed | Japan | A Method and Apparatus for Chemical Mechanical Polishing |
| 09292079 | 6211051 | 1999-04-14 | 2001-04-03 | Granted | United States of America | Reduction of plasma damage at contact etch in MOS integrated circuits |

| Dual purpose retaining ring and polishing pad conditioner | United States of America | Fynired | 1999-12-21 | 1997-07-17 | 6004193 | U880E0EU |
|---|--------------------------|-----------|------------|------------|-----------|---------------|
| therefor | United States of America | Granted | 2000-02-22 | 1997-11-10 | 6028014 | 08966637 |
| Plasma-enhanced oxide process optimization and material and apparatus | | | | | | |
| Semiconductor integrated circuit core probing for failure analysis | United States of America | Granted | 1999-08-10 | 1997-12-03 | 5936876 | 08984003 |
| Shimming substrate holder assemblies to produce more uniformly polished substrate surfaces | United States of America | Expired | 1999-10-05 | 1997-10-30 | 5961375 | 08960925 |
| Apparatus and method for electrical determination of delamination at one or more interfaces within a semiconductor wafer | United States of America | Granted | 2000-05-23 | 1997-12-19 | 6066561 | 08995260 |
| Method and system for alignment of openings in semiconductor fabrication | United States of America | Granted | 1999-12-07 | 1998-04-02 | 5998226 | 09054279 |
| Silicon wafer or die strength test fixture using high pressure fluic | United States of America | Granted | 1999-11-30 | 1998-05-04 | 5992242 | 09072915 |
| Gas Control Structure For Cvd Chamber | United States of America | Abandoned | | 1997-11-26 | | 08979733 |
| In-situ etch of CVD chamber | United States of America | Expired | 1999-06-22 | 1997-11-26 | 5914001 | 08979734 |
| High selectivity SiC etch in integrated circuit fabrication | United States of America | Granted | 2004-06-01 | 2001-08-13 | 6743725 | 09928570 |
| In-situ chemical-mechanical polishing slurry formulation for compensation of polish pad degradation | United States of America | Granted | 2000-05-23 | 1998-07-08 | 6066266 | 09112403 |
| Generating non-planar topology on the surface of planar and near-planar substrates | United States of America | Granted | 2000-09-05 | 1998-07-06 | 6114215 | 09111271 |
| Thick metal top layer | United States of America | Lapsed | 2005-03-15 | 2002-11-26 | 6867488 | 10304974 |
| Method of testing the processing of a semiconductor wafer on a CMP apparatus | United States of America | Granted | 2004-04-27 | 2001-09-07 | 6727107 | 09948808 |
| Process for CMP removal of excess trench or via filler metal which inhibits formation of concave regions on oxide surface of integrated circuit structure | United States of America | Granted | 2002-05-21 | 2000-10-30 | 6391768 | 09703616 |
| Process For Forming Integrated Circuit Structure With Improved Metal Silicide Contacts Using Notched Sidewall Spacer On Gate Electrode, And Resulting Structure | Korea, Republic of (KR) | Lapsed | 2005-06-24 | 1998-08-20 | 499194 | 1019980033782 |
| Method and apparatus for protecting functions imbedded within an integrated circuit from reverse engineering | United States of America | Expired | 1999-01-19 | 1996-03-28 | 5861652 | 08623470 |
| Method for fabricating a low trigger voltage silicon controlled rectifier and thick field device | United States of America | Expired | 1999-10-12 | 1996-05-21 | 5966599 | 08651018 |
| Standardized gas isolation box (GIB) installation | United States of America | Expired | 1999-06-29 | 1997-09-04 | 5915414 | 08923676 |
| Arrangement and method for controlling the transmission of a light signal based on intensity of a received light signal | United States of America | Lapsed | 2005-11-29 | 2001-07-19 | 6970622 | 09909175 |
| Method and apparatus for detecting an endpoint polishing layer by transmitting infrared light signals through a semiconductor wafer | United States of America | Granted | 2000-06-13 | 1998-07-08 | 6074517 | 09112222 |
| Tunable Dielectric Constant Oxide and Method of Manufacture | Taiwan | Lapsed | 2001-10-08 | 1998-03-17 | 133913 | 87103907 |
| Fabrication of metal-insulator-metal capacitive structures | United States of America | Granted | 2001-01-23 | 1998-12-17 | 6177305 | 09213847 |
| litle | Country | Status | GrantDate | FiledDate | Patentino | Appino |

| Multiple Operating Voltage Vertical Replacement-Gate (VRG) Transistor | Japan | Abandoned | | 2012-05-07 | | 2012105770 |
|--|--------------------------|-----------|------------|------------|----------|------------|
| LOW MUTUAL INDUCTANCE MATCHED INDUCTORS | United States of America | Granted | 2009-05-19 | 2006-09-22 | 7535330 | 11534340 |
| Method And Structure For DC And RF Shielding Of Integrated Circuits | Japan | Abandoned | | 2011-04-06 | | 201184505 |
| Uniform and repeatable plasma processing | United States of America | Expired | 1995-12-12 | 1994-07-29 | 5474648 | 08283296 |
| A Bipolar Junction Transistor Having A High Germanium Concentration In A Silicon-Germanium Layer And A Method For Forming The Bipolar Junction Transistor | Japan | Lapsed | 2015-03-13 | 2005-03-10 | 5710714 | 2013174500 |
| Power mesh bridge | United States of America | Granted | 2002-12-10 | 2001-03-14 | 6492736 | 09808441 |
| Automating photolithography in the fabrication of integrated circuits | United States of America | Expired | 1997-09-02 | 1995-08-08 | 5663076 | 08512678 |
| Process monitor usig impedance controlled I/O controller | United States of America | Expired | 1997-08-05 | 1996-04-04 | 5654895 | 08627622 |
| Process for forming metal-filled openings in low dielectric constant dielectric material while inhibiting via poisoning | United States of America | Granted | 2003-01-07 | 2001-05-02 | 6503840 | 09848758 |
| Control of reaction rate in formation of low k carbon-containing silicon oxide dielectric material using organosilane, unsubstituted silane, and hydrogen peroxide reactants | United States of America | Granted | 2003-05-13 | 2001-12-11 | 6562735 | 10015255 |
| Microelectronic circuit including silicided field-effect transistor elements that bifunction as interconnects | United States of America | Expired | 1998-06-30 | 1997-01-31 | 5773855 | 08792479 |
| Microelectronic integrated circuit including hexagonal semiconductor gate device | United States of America | Expired | 1996-07-23 | 1995-03-01 | 5539246 | 08396560 |
| Silicidation process with etch stop | United States of America | Expired | 1997-12-16 | 1995-06-07 | 5698468 | 08486803 |
| Leak detection system for a gas manifold of a chemical vapor deposition apparatus | United States of America | Expired | 1997-03-25 | 1995-08-28 | 5614249 | 08520030 |
| Variable width low profile gate array input/output architecture | United States of America | Expired | 1998-06-02 | 1996-01-25 | 5760428 | 08596894 |
| Process for forming self-aligned conductive plugs in multiple insulation levels in integrated circuit structures and resulting product | United States of America | Expired | 1999-11-16 | 1996-11-21 | 5985746 | 08754696 |
| Simplified hole interconnect process | United States of America | Expired | 1999-02-09 | 1997-01-22 | 5869395 | 08786695 |
| Semiconductor device and fabrication method employing a palladiumplated heat spreader substrate | United States of America | Granted | 1999-10-26 | 1997-11-04 | 5973398 | 08963813 |
| Use of ethylene glycol as a corrosion inhibitor during cleaning after metal chemical mechanical polishing | United States of America | Expired | 1999-04-13 | 1997-08-26 | 5893756 | 08918483 |
| Automated endpoint detection system during chemical-mechanical polishing | United States of America | Expired | 1999-11-16 | 1997-06-12 | 5985679 | 08874055 |
| Effective silicide blocking | United States of America | Expired | 2000-02-01 | 1997-09-04 | 6020242 | 08926590 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Defect analysis using a vield vehicle | United States of America | Granted | 2007-10-16 | 2005-10-11 | 7284213 | 11247517 |
|---|-------------------------------|-----------|------------|------------|------------|---------------|
| Reduced capacitance resistors | United States of America | Granted | 2007-07-10 | 2004-12-06 | 7242074 | 11005765 |
| Method for fabricating planar semiconductor wafers | United States of America | Granted | 2007-02-20 | 2004-10-14 | 7179736 | 10966074 |
| CMOS varactor with constant dC/dV characteristic | United States of America | Lapsed | 2004-11-30 | 2001-12-28 | 6825546 | 10035346 |
| Converter device | United States of America | Lapsed | 2005-07-05 | 2001-06-14 | 6914786 | 09881151 |
| Method and sample for radiation microscopy including a particle beam channel formed in the sample source | United States of America | Granted | 2008-09-30 | 2005-12-29 | 7429733 | 11323405 |
| Method and system for area efficient charge-based capacitance measurement | United States of America | Lapsed | 2006-09-12 | 2005-05-27 | 7106073 | 11140142 |
| Method and apparatus for chemical-mechanical polishing | United States of America | Granted | 2002-01-22 | 1998-09-03 | 6340434 | 09148028 |
| A Process for Fabricating Integrated Circuit Devices Having Thin Film Transistors | Japan | Lapsed | 2010-04-30 | 2009-06-17 | 4505036 | 2009143777 |
| Processing for forming integrated circuit structure with low dielectric constant material between closely spaced apart metal lines | United States of America | Granted | 2003-05-06 | 2001-06-27 | 6559033 | 09892250 |
| Low Dielectric Constant Silicon Oxide-Based Dielectric Layer for Integrated Circuit Structures Having Improved Compatibility with Via Filler Materials, and Method of Making Same | European Patent | Lapsed | | 2000-10-18 | | 001226885 |
| Semiconductor Device Free Of LDD Regions | Japan | Granted | 2013-11-08 | 2009-10-27 | 5404308 | 2009246032 |
| A Bipolar Junction Transistor Having A High Germanium Concentration In A Silicon-Germanium Layer And A Method For Forming The Bipolar Junction Transistor | European Patent | Abandoned | | 2005-03-10 | | 131550428 |
| Integrated circuit structure having reduced cross-talk and method of making same | United States of America | Expired | 1997-11-18 | 1996-07-24 | 5689134 | 08685772 |
| Interconnect-Embedded Metal-Insulator-Metal Capacitor and Method of Fabricating Same | Germany (Federal Republic of) | Granted | 2008-03-12 | 2001-01-30 | 60133155.9 | 011016839 |
| A Bipolar Junction Transistor Having A High Germanium Concentration In A Silicon-Germanium Layer And A Method For Forming The Bipolar Junction Transistor | European Patent | Abandoned | | 2005-03-10 | | 057254047 |
| Method of forming polysilicon local interconnects | United States of America | Expired | 1998-07-14 | 1996-05-20 | 5780347 | 08650476 |
| Silicon controller rectifier (SCR) with capacitive trigger | United States of America | Expired | 1997-06-10 | 1995-06-07 | 5637887 | 08475586 |
| An Integrated Circuit Including ESD Circuits For A Multi-Chip Module And A Method Therefor | Japan | Abandoned | | 2012-04-26 | | 2012100569 |
| CMP slurry recycling apparatus and method for recycling CMP slurry | United States of America | Granted | 2002-07-02 | 2000-12-06 | 6413151 | 09730704 |
| A Bipolar Junction Transistor Having A High Germanium Concentration In A Silicon-Germanium Layer And A Method For Forming The Bipolar Junction Transistor | Korea, Republic of (KR) | Granted | 2012-12-21 | 2012-06-11 | 10-1216580 | 1020127015010 |
| litle | Country | Status | GrantDate | FiledDate | Patentino | AppNo |

| | Date patrio | Elled Date | GrantDato | Statue . | Country | Title |
|-----------|-------------|------------|------------|----------|--------------------------|--|
| 11397252 | 8053824 | 2006-04-03 | 2011-11-08 | PQ. | United States of America | Interdigitated Mesh To Provide Distributed, HIgh Quality Factor Capacitive Coupling |
| | 7137098 | 2004-08-27 | 2006-11-14 | | United States of America | Pattern component analysis and manipulation |
| 60002275 | | 1995-08-14 | | | United States of America | A Process For Semiconductor Device Fabrication |
| 60426842 | | 2002-11-15 | | | United States of America | In-Situ Removal Of Surface Impurities Prior To As Doped Poly Dep |
| 60552308 | | 2004-03-10 | | | United States of America | Creation of A High Ge Concentration SiGe Layer In BiCMOS Processing Through Thermal Oxidation of the SiGe Base Layer |
| 60541878 | | 2004-02-04 | | Expired | United States of America | Structure For Improved Heat Conduction For Semiconductor Devices |
| | | | | | | Method Of Making A Graded Grown, High Quality Oxide Layer For A Semiconductor |
| 60115717 | | 1999-01-12 | | Expired | United States of America | Device |
| 60117242 | | 1999-01-26 | | Expired | United States of America | Device Comprising Thermally Stable, Low Dielectric Constant Material |
| 10971961 | 7259083 | 2004-10-22 | 2007-08-21 | Granted | United States of America | Local interconnect manufacturing process |
| 60115532 | | 1999-01-12 | | Expired | United States of America | Novel Methods To Fabricate MOM Capacitors |
| 10117487 | 6878406 | 2002-04-05 | 2005-04-12 | Lapsed | United States of America | Dynamic use of process temperature |
| 062546304 | | 2006-09-06 | | Lapsed | European Patent | Robust Shallow Trench Isolation Structures And A Method For Forming Shallow Trench Isolation Structures |
| 60180809 | | 2000-02-07 | | Expired | United States of America | Improvement Of Thick Photoresist (PR) Integrity For High-Current High-Dose High-Energy Ion Implantation Using A Novel Thermal And UV-Irradiation Treatment |
| 60174566 | | 2000-01-05 | | Expired | United States of America | An Integrated Circuit And A Method Of Making An Integrated Circuit |
| 10867014 | 7013192 | 2004-06-14 | 2006-03-14 | Lapsed | United States of America | Substrate contact analysis |
| 11269275 | 8076779 | 2005-11-08 | 2011-12-13 | | United States of America | Reduction of macro level stresses in copper/Low-K wafers Process for etching a controllable thickness of oxide on an integrated circuit structure on a semiconductor substrate using nitrogen plasma and |
| 09972481 | 6667536 | 2001-10-05 | 2003-12-23 | Lapsed | United States of America | Thin Film Multi-Layer High Q Transformer Formed In A Semiconductor Substrate |
| 60140666 | | 1999-06-24 | | Expired | United States of America | Method Of Making A Graded, High Quality Oxide Layer For A Semiconductor Device |
| 60096581 | | 1998-08-14 | | Expired | United States of America | Process For Fabricating Device Comprising Lead Zirconate Titanate |
| 09271084 | 6531751 | 1999-03-17 | 2003-03-11 | Granted | United States of America | Semiconductor Device With Increased Gate Insulator Lifetime |
| 60141656 | | 1999-06-30 | | Expired | United States of America | Impact Of Post Window Etch Cleans Process On Reliability Of 0.25 (*mm Vintage Windows |

| Process For Device Fabrication Using A High-Energy Boron Implant | United States of America | Granted | 2000-10-24 | 1998-08-10 | 6136672 | 09131860 |
|---|--------------------------|---------|------------|------------|----------|------------|
| Film Thickness | United States of America | Expired | | 1995-10-16 | | 60007002 |
| A Process For Fabricating A Device Using Polarized Light To Determine | | | | | | |
| A 3-Step Passivation-Depassivation-Passivation D 2 Annealing Process For Hot Carrier Immunity And Transistor Matching | United States of America | Expired | | 1999-01-14 | | 60115881 |
| Use Of Titanium-Tantalum Alloy As A Diffusion Barrier Material For CopperInterconnects | United States of America | Expired | | 1999-05-24 | | 60135565 |
| Field Emitting Device Comprising Field-Concentrating Nanoconductor Assembly And Method For Making The Same | United States of America | Granted | 2003-03-25 | 1999-08-06 | 6538367 | 09369802 |
| An Energy-Sensitive Resist Material And A Process For Device Fabrication Using An Energy-Sensitive Resist Material | United States of America | Expired | | 1996-03-08 | | 60013093 |
| Electrochemical Abatement Of Perfluorinated Compounds | United States of America | Expired | | 1999-08-16 | | 60149036 |
| A Bipolar Junction Transistor Having A High Germanium Concentration In A Silicon-Germanium Layer And A Method For Forming The Bipolar Junction Transistor | Japan | Granted | 2013-10-25 | 2005-03-10 | 5393027 | 2007503058 |
| Article Comprising Aligned Carbon Nanotubes With Reduced Diameter And Method For Making The Same | United States of America | Expired | | 1999-07-22 | | 60145127 |
| Process control data collection | United States of America | Granted | 2007-11-20 | 2004-03-12 | 7299158 | 10799851 |
| Anti-reflective coatings for use at 248 nm and 193 nm | United States of America | Granted | 2004-02-03 | 2001-12-13 | 6686272 | 10020084 |
| Parametric outlier detection | United States of America | Lapsed | 2006-06-13 | 2004-08-27 | 7062415 | 10928292 |
| A Resistor Located On A Semiconductor Substrate And A Method of Manufacture Therefor | United States of America | Expired | | 2001-09-28 | | 60326050 |
| manufacturing using ID cells | United States of America | Lapsed | 2005-09-06 | 2003-11-03 | 6939727 | 10701328 |
| Method for performing statistical post processing in semiconductor | | | | | | |
| Technique To Fabricate Gate Mask Photo Alignment Marks For STI | United States of America | Expired | | 1999-01-12 | | 60115527 |
| Sonic assisted strengthening of gate oxides | United States of America | Granted | 2002-04-16 | 1998-07-10 | 6372520 | 09113594 |
| Process For Fabricating A Device Using Polarized Light To Determine Film Thickness | United States of America | Expired | 1998-11-10 | 1996-09-17 | 5835221 | 08714909 |
| Process For Fabricating Device Comprising Lead Zirconate Titanate | United States of America | Granted | 2001-06-19 | 1999-01-22 | 6248394 | 09235735 |
| Method For Making An Integrated Circuit Capacitor Including Tantalum Pentoxide | United States of America | Granted | 2001-07-24 | 1999-06-30 | 6265260 | 09345556 |
| A Process For Device Fabrication In Which The Plasma Etch Is Controlled By Monitoring Optical Emission | United States of America | Expired | | 1995-10-12 | | 60005141 |
| A Spiral Inductor Formed In A Semiconductor Substrate | United States of America | Expired | | 2003-09-30 | | 60507335 |
| An Integrated Circuit Device Having A Planar Interlevel Dielectric Layer | United States of America | Granted | 2001-08-14 | 1999-08-17 | 6274933 | 09376233 |
| Method For Making An Integrated Circuit Including Alignment Marks | United States of America | Granted | 2002-04-09 | 1999-06-30 | 6368972 | 09345039 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
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| | United States of America | Crantod | 2008-10-21 | 7000-08-30 | 3/102//2 | 000000000000000000000000000000000000000 |
|---|--------------------------|---------|------------|------------|------------|---|
| A Polishing Pad Having A Water-Repellant Film Thereon And A Method Of Manufacture Therefor | United States of America | Granted | 2002-08-27 | 2000-02-28 | 6439968 | 09514832 |
| Method And Apparatus For Dark Spin Rinse/Dry Semiconductor Processing | United States of America | Granted | 2002-03-26 | 2000-02-22 | 6361614 | 09510015 |
| Abnormal Photoresist Line\(slSpace Profile Detection Through Signal Processing Of Metrology Waveform | United States of America | Granted | 2004-03-23 | 2002-05-24 | 6708574 | 10156242 |
| Process For Fabricating A Semiconductor Device Having A Metal Oxide Or A Metal Silicate Gate Dielectric Layer | United States of America | Granted | 2002-11-12 | 2000-08-17 | 6479404 | 09641160 |
| Sputtering Method For Forming Dielectric Films | United States of America | Granted | 2001-09-18 | 1999-12-23 | 6290822 | 09472332 |
| A Process For Device Fabrication In Which The Plasma Etch Is Controlled By Monitoring Optical Emission | United States of America | Expired | 1999-03-02 | 1996-08-27 | 5877032 | 08703756 |
| Oxide Etch | United States of America | Granted | 2003-01-07 | 2000-07-07 | 6503841 | 09611844 |
| Method for creating barrier layers for copper diffusion | United States of America | Lapsed | 2006-02-14 | 2003-11-24 | 6998343 | 10721971 |
| Complimentary metal oxide semiconductor capacitor and method for making same | United States of America | Lapsed | 2005-06-21 | 2003-10-22 | 6909591 | 10690861 |
| Device Comprising Thermally Stable, Low Dielectric Constant Material | United States of America | Granted | 2002-10-22 | 1999-04-21 | 6469390 | 09296001 |
| Composition with EMC shielding characteristics | United States of America | Granted | 2004-07-20 | 2001-06-12 | 6765806 | 09879783 |
| A Method Of Inmproving Electromigration In Semiconductor Device Manufacturing Processes | United States of America | Granted | 2002-04-02 | 2000-06-14 | 6365503 | 09594189 |
| A Bipolar Junction Transistor Having A High Germanium Concentration In A Silicon-Germanium Layer And A Method For Forming The Bipolar Junction Transistor | Korea, Republic of (KR) | Granted | 2012-08-07 | 2005-03-10 | 10-1173526 | 1020067018437 |
| Multi-Layer Inductor Formed In A Semiconductor Substrate And Having A Core Of Ferromagnetic Material | United States of America | Granted | 2006-11-07 | 2004-10-27 | 7132297 | 10513121 |
| Integrated circuit carrier apparatus method and system | United States of America | Granted | 2007-01-23 | 2003-11-14 | 7166492 | 10713951 |
| Process For Controlling Alignment In A Lithographic Process And Apparatus Therefor | United States of America | Expired | | 2001-06-01 | | 60294566 |
| Process For Device Fabrication Using A High-Energy Boron Implant | United States of America | Expired | | 1998-04-17 | | 60082076 |
| X-Ray System | United States of America | Expired | | 1999-12-20 | | 60172654 |
| Monitoring And Control Of A Fabrication Process | United States of America | Granted | 2011-07-05 | 2005-06-10 | 7972440 | 10505197 |
| Multi-Layered Metal Silicide Resistor For Si IC's | United States of America | Granted | 2002-03-19 | 2000-01-10 | 6359339 | 09480224 |
| High performance voltage control diffusion resistor | United States of America | Lapsed | 2006-07-04 | 2003-09-23 | 7071811 | 10668875 |
| An Energy-Sensitive Resist Material And A Process For Device Fabrication Using An Energy-Sensitive Resist Material | United States of America | Expired | | 1997-10-02 | | 60060869 |
| Method and control system for improving CMP process by detecting and reacting to harmonic oscillation | United States of America | Lapsed | 2005-12-06 | 2004-02-17 | 6971944 | 10779966 |
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| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
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| 09483297 | 6465132 | 2000-01-14 | 2002-10-15 | Granted | United States of America | Article Comprising Small Diameter Nanowires And Method For Making The Same |
| | 6187665 | 1999-08-23 | 2001-02-13 | | United States of America | A process For Deuterium Passivation And Hot Carrier Immunity |
| | 7556048 | 2003-09-30 | 7009-07-07 | ansed | United States of America | In-Situ Removal Of Surface Impurities Prior TO Arsenic-Doped Polysilicon In The Fabrication Of Heteroiuntion Biloplar Transistor |
| | 6707063 | 1999-10-25 | 2001-10-02 | Grap+od | United States of America | In-Situ Nano-Interconnected Circuit Devices And Method For Making The |
| | 6153901 | 1999-07-30 | 2000-11-28 | Granted | United States of America | Integrated Circuit Capacitor Including Anchored Plug |
| 09366388 | 6560735 | 1999-08-03 | 2003-05-06 | Granted | United States of America | Methods And Apparatus For Testing Integrated Circuits |
| 10650395 | 7067882 | 2003-08-28 | 2006-06-27 | Lapsed | United States of America | High quality factor spiral inductor that utilizes active negative capacitance |
| 09521768 | 6319095 | 2000-03-09 | 2001-11-20 | | United States of America | Colloidal Suspension Of Abrasive Particles Containing Magnesium As CMP Slurry |
| 09451053 | 6576980 | 1999-11-30 | 2003-06-10 | Granted | United States of America | Surface Treatment Anneal Of Hydrogenated Silicon-Oxy-Carbide Dielectric Layer |
| 09334977 | 6417570 | 1999-06-17 | 2002-07-09 | Granted | United States of America | Layered Dielectric Film Structure Suitable For Gate Dielectric Application In Sub\(mi0.25 ìm Technologies |
| 09140275 | 6080625 | 1998-08-26 | 2000-06-27 | Granted | United States of America | Method For Making Dual-Polysilicon Structures In Integrated Circuits |
| 10723701 | 7183787 | 2003-11-26 | 2007-02-27 | Granted | United States of America | Contact resistance device for improved process control |
| 2003572051 | 4737933 | 2003-02-24 | 2011-05-13 | Lapsed | Japan | Monitoring And Control Of A Fabrication Process |
| 09653297 | 6548892 | 2000-08-31 | 2003-04-15 | Granted | United States of America | Low K Dielectric Insulator and Method of Forming Semiconductor Circuit Structures |
| 10026407 | 6730588 | 2001-12-20 | 2004-05-04 | Granted | United States of America | Method of forming SiGe gate electrode |
| 09759120 | 6509242 | 2001-01-12 | 2003-01-21 | Granted | United States of America | Heterojunction Bipolar Transistor |
| 10736386 | 7653523 | 2003-12-15 | 2010-01-26 | Lapsed | United States of America | Method For Calculating High-Resolution Wafer Parameter Profiles |
| 09121284 | 6013958 | 1998-07-23 | 2000-01-11 | Granted | United States of America | Apparatus and Method for Integrated Circuit With Variable Capacitor High performance diode implanted voltage controlled p-type diffusion |
| 10/30334 | 6111750 | 1999-01-15 | 2000-08-29 | Granted | United States of America | Flectronic Apparatus |
| | 6283812 | 1999-01-25 | 2001-09-04 | | United States of America | Article Comprising Aligned, Truncated Carbon Nanotubes And Process For Fabricating Article |
| 09277778 | 6218255 | 1999-03-29 | 2001-04-17 | Granted | United States of America | Method Of Making A Capacitor |
| 09911364 | 6844236 | 2001-07-23 | 2005-01-18 | Granted | United States of America | Method And Structure For DC And RF Shielding Of Integrated Circuits |
| | 7245758 | 2003-08-20 | 2007-07-17 | Granted | United States of America | Whole-wafer photoemission analysis |
| 09311631 | 6358865 | 1999-05-14 | 2002-03-19 | Granted | United States of America | Oxidation Of Silicon Using Fluorine Implant |

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|---|--------------------------|---------|------------|------------|---------|----------|
| Pad conditioner setup | United States of America | Lapsed | 2006-07-25 | 2003-09-22 | 7081037 | 10668021 |
| Shallow trench isolation structure for laser thermal processing | United States of America | Granted | 2004-05-11 | 2001-10-24 | 6734081 | 09999848 |
| Field Emission Devices Employing Improved Emitters On Metal Foil And Methods For Making Such Devices | United States of America | Expired | 1997-07-15 | 1995-11-09 | 5648699 | 08555594 |
| Process For Forming Integrated Capacitors | United States of America | Expired | 1996-12-31 | 1995-12-06 | 5589416 | 08568040 |
| Article Comprising An Inductor | United States of America | Granted | 2000-08-08 | 1998-09-12 | 6101371 | 09152189 |
| Method of translating a net description of an integrated circuit die | United States of America | Lapsed | 2005-03-08 | 2003-09-08 | 6865435 | 10658017 |
| Apparatus For Processing Silicon Device With Improved Temperature Control | United States of America | Granted | 1999-12-14 | 1998-05-18 | 6002113 | 09080430 |
| Deuterated Dielectric And Polysilicon Film-Based Semiconductor Devices And Method Of Manufacture Thereof | United States of America | Expired | 2000-02-08 | 1997-04-28 | 6023093 | 08847704 |
| Semiconductor Device Having a Signal Pin with Multiple Connections | United States of America | Granted | 2000-08-22 | 1999-01-07 | 6107684 | 09226730 |
| A Process For Fabricating Integrated Circuit Devices Having Thin Film Transistors | United States of America | Granted | 2001-03-06 | 1999-12-07 | 6197663 | 09456210 |
| System And Method Of Manufacturing Semicustom Integrated Circuits Using Reticle Primitives From A Library And Interconnect Reticles | United States of America | Granted | 2001-02-20 | 1998-05-21 | 6192290 | 09082924 |
| Thick Oxide Region In A Semiconductor Device | United States of America | Lapsed | 2006-06-27 | 2004-09-29 | 7067890 | 10953750 |
| Lithographic Process For Device Fabrication Using Dark-Field Illumination | United States of America | Granted | 2002-04-30 | 1999-04-01 | 6379868 | 09283528 |
| A Semiconductor Device Barrier Layer | United States of America | Granted | 2004-02-03 | 2002-05-21 | 6686662 | 10153231 |
| System and Method of Manufacturing Semicustom Reticles Using Reticle Primitives | United States of America | Granted | 2001-09-04 | 1998-07-01 | 6284413 | 09108848 |
| Article Comprising Enhanced Nanotube Emitter Structure And Process For Fabricating Article | United States of America | Granted | 2001-06-26 | 1999-01-25 | 6250984 | 09236966 |
| Plate Capacitor Structure And Fabrication Method Therefor In A Dual Damascene Process | United States of America | Granted | 2004-08-31 | 2002-09-30 | 6784478 | 10260693 |
| Silicon-Rich Low Thermal Budget Silicon Nitride For Integrated Circuits | United States of America | Granted | 2005-09-06 | 2002-09-30 | 6940151 | 10261463 |
| Manufacture Of Mosfet Devices | United States of America | Granted | 2000-08-15 | 1998-09-15 | 6103607 | 09153522 |
| A Capacitor In An Integrated Circuit And A Method Of Manufacturing An Integrated Circuit | United States of America | Granted | 2002-02-19 | 1998-08-26 | 6348393 | 09140270 |
| Semiconductor Device Having Regions Of Insulating Material Formed In A Semiconductor Substrate And Process Of Making The Device | United States of America | Granted | 2002-02-26 | 1999-09-01 | 6350659 | 09388297 |
| Method For Producing Oriented Piezoelectric Films | United States of America | Granted | 2000-11-28 | 1999-07-29 | 6153268 | 09363758 |
| | | 9 | | | | |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|----------|--------------|------------|------------|---------|--------------------------|--|
| 08957122 | 6556703 | 1997-10-24 | 2003-04-29 | Expired | United States of America | Scanning Electron Microscope System And Method Of Manufacturing An Integrated Circuit |
| 08538317 | 7777 7777 | 1995-10-03 | 1006-00-03 | | United States of America | Compensation Of The Temperature Coefficient Of The Dielectric Constant |
| | 6323537 | 1999-03-29 | | Granted | United States of America | A Capacitor For An Integrated Circuit |
| 10675569 | 7137400 | 2003-09-30 | 2006-11-21 | | United States of America | Bypass Loop Gas Flow Calibration |
| | | | | | | Fabrication Process For A Semiconductor Device Having A Metal Oxide Dielectric Material With A High Dielectric Constant, Annealed With A |
| 10151887 | 6797525 | 2002-05-22 | 2004-09-28 | Granted | United States of America | Buffered Anneal Process |
| 09742855 | 6625250 | 2000-12-19 | 2003-09-23 | Granted | United States of America | Optical Structures And Methods For X-Ray Applications |
| 08534356 | 5642014 | 1995-09-27 | 1997-06-24 | Expired | United States of America | Self-Powered Devices |
| 09310701 | 6492647 | 1999-05-07 | 2002-12-10 | Granted | United States of America | Improved Wehnelt Gun For Electron Lithography |
| 08509930 | 5739562 | 1995-08-01 | 1998-04-14 | Expired | United States of America | Combined Photogate And Photodiode Active Pixel Image Sensor |
| 10180910 | 6847077 | 2002-06-25 | 2005-01-25 | Granted | United States of America | Capacitor For A Semiconductor Device And Method For Fabrication Therefor |
| 10767205 | 7037820 | 2004-01-30 | 2006-05-02 | Granted | United States of America | Cross-Fill Pattern For Metal Fill Levels, Power-Supply Filtering, And Analog Circuit Shielding |
| 09409115 | 6322934 | 1999-09-30 | 2001-11-27 | Granted | United States of America | Method For Making Integrated Circuits Including Features With A Relatively Small Critical Dimension |
| 10629496 | 6818516 | 2003-07-29 | 2004-11-16 | Lapsed | United States of America | Selective high k dielectrics removal |
| 09364366 | 6204186 | 1999-07-30 | 2001-03-20 | Granted | United States of America | Method Of Making Integrated Circuit Capacitor Including Tapered Plug |
| 08380774 | 5598056 | 1995-01-31 | 1997-01-28 | Expired | United States of America | Multilayer Pillar Structure For Improved Field Emission Devices |
| 08903974 | 6566224 | 1997-07-31 | 2003-05-20 | Expired | United States of America | Process For Device Fabrication |
| 08355787 | 5670376 | 1994-12-14 | 1997-09-23 | Expired | United States of America | Methodology For Monitoring Solvent Quality |
| 09178720 | 6218077 | 1998-10-26 | 2001-04-17 | Granted | United States of America | Method Of Manufacturing An Integrated Circuit Using A Scanning System And A Scanning System |
| 09209787 | 6339246 | 1998-12-11 | 2002-01-15 | Granted | United States of America | Tungsten Silicide Nitride As An Electrode For Tantalum Pentoxide Devices |
| 08431355 | 5620573 | 1995-04-28 | 1997-04-15 | Expired | United States of America | Reduced Stress Tungsten Deposition |
| 08581665 | 5681763 | 1995-12-29 | 1997-10-28 | Expired | United States of America | Method For Making Bipolar Transistors Having Indium Doped Base |
| 09430147 | 6294465 | 1999-10-29 | 2001-09-25 | Granted | United States of America | Method For Making Integrated Circuits Having Features With Reduced Critical Dimensions |
| 08350439 | 5545916 | 1994-12-06 | 1996-08-13 | | United States of America | High Q, Integrated Inductors |
| 09388166 | 6436187 | 1999-09-01 | 2002-08-20 | Granted | United States of America | Process For Fabricating Article Having Substantial Three-Dimensional Order |
| 08751472 | 5736749 | 1996-11-19 | 1998-04-07 | Expired | United States of America | Integrated Circuit Device With Inductor Incorporated Therein |
| 09878820 | 6875702 | 2001-06-11 | 2005-04-05 | Lapsed | United States of America | Plasma treatment system |

| High Dielectric Constant Gate Oxides For Silicon-Based Devices | United States of America | Granted | 2002-06-11 | 2000-02-07 | 6404027 | 09499411 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Interconnections To Copper IC's | United States of America | Granted | 2003-09-16 | 2000-04-10 | 6620720 | 09546037 |
| Silicon-On-Insulator (SOI) Semiconductor Structure With Trench Including A Conductive Layer | United States of America | Granted | 2003-03-25 | 2000-07-07 | 6538283 | 09611907 |
| A Method For Reducing Dishing Related Issues During The Formation Of Shallow Trench Isolation Structures | United States of America | Granted | 2002-12-31 | 2000-06-02 | 6500729 | 09586384 |
| Visual wear confirmation polishing pad | United States of America | Lapsed | 2008-10-28 | 2003-04-23 | 7442113 | 10421421 |
| Metal To Metal Capacitor Apparatus And Method For Making | United States of America | Expired | 1999-05-11 | 1997-09-17 | 5903493 | 08932005 |
| Field Emission Display Having Corrugated Support Pillars and Method for Manufacturing | United States of America | Expired | 1996-10-01 | 1995-01-31 | 5561340 | 08381262 |
| Wafer Handling Apparatus and Method | United States of America | Expired | 2002-12-10 | 1996-11-15 | 6491732 | 08749719 |
| Organic P-Channel | United States of America | Expired | 1997-04-29 | 1996-01-16 | 5625199 | 08587426 |
| Article Comprising Complementary Circuit with Inorganic N-Channel and | | | | | | |
| Integrated Circuit Fabrication | United States of America | Expired | 1998-10-13 | 1995-12-11 | 5821147 | 08570429 |
| Reverse Side Etching for Producing Layers with Strain Variation | United States of America | Expired | 1996-07-02 | 1994-12-30 | 5532510 | 08366515 |
| silicon epitaxial growth | United States of America | Granted | 2008-09-30 | 2003-06-04 | 7429749 | 10455489 |
| Strained-silicon for CMOS device using amorphous silicon deposition or | | | | | | |
| Electron field emitters comprising particles cooled with low voltage emitting material | United States of America | Expired | 1997-04-22 | 1994-10-31 | 5623180 | 08332179 |
| Capacitor Comprising Improved Taox-Based Dielectric | United States of America | Expired | 1999-11-02 | 1997-05-23 | 5977582 | 08862907 |
| Mechanical Polishing | United States of America | Granted | 1999-10-19 | 1997-12-01 | 5967885 | 08982109 |
| Method Of Manufacturing An Integrated Circuit Using Chemical | | | | | | |
| Method Of Etching Silicon Nitride | United States of America | Expired | 1995-12-05 | 1994-08-05 | 5472562 | 08286606 |
| Multiple Layer Tungsten Deposition Process | United States of America | Expired | 1996-02-06 | 1994-12-30 | 5489552 | 08366529 |
| Self-Aligned Opaque Regions For Attenuating Phase-Shifting Masks | United States of America | Expired | 1996-12-31 | 1994-12-30 | 5589303 | 08366952 |
| MOS Image Sensor | United States of America | Expired | 2000-10-31 | 1997-06-20 | 6141050 | 08879926 |
| Article Comprising Aligned | United States of America | Granted | 2004-05-25 | 1999-10-18 | 6741019 | 09420157 |
| Laser-Assisted Particle Analysis | United States of America | Expired | 1997-05-20 | 1995-01-17 | 5631462 | 08373732 |
| Processes | United States of America | Granted | 2000-11-21 | 1998-09-10 | 6150271 | 09151077 |
| Differential Temperature Control In Chemical Mechanical Polishing | | | | | | |
| Article Comprising alpha-Hexathienyl | United States of America | Expired | 1997-08-19 | 1995-03-02 | 5659181 | 08393494 |
| Method Of Forming A T-Shaped Gate | United States of America | Expired | 1999-11-09 | 1997-09-22 | 5981319 | 08935121 |
| Integrated Circuit With Twin Tub | United States of America | Expired | 2000-01-25 | 1996-12-31 | 6017787 | 08775490 |
| Backside Dielectric And Implantation Electron Flood | United States of America | Expired | 1997-08-12 | 1994-11-22 | 5656510 | 08344318 |
| Method For Manufacturing Gate Oxide Capacitors Including Wafer | | | | | | |
| METHOD FOR FABRICATING SEMICONDUCTOR DEVICES | United States of America | Granted | 2001-03-13 | 1998-06-15 | 6200734 | 09094920 |
| Article Comprising An Oxide Layer On GaN | United States of America | Expired | 1999-06-15 | 1997-10-10 | 5912498 | 08948874 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Methods And Apparatus For Testing Integrated Circuits | Taiwan | Lapsed | 2002-03-21 | 2000-11-13 | NI-152144 | 89115497 |
|---|--------------------------|---------|------------|------------|-----------|-----------|
| Control | Taiwan | Lapsed | 2000-11-01 | 1999-04-01 | NI-122696 | 88105177 |
| Apparatus For Processing Silicon Device With Improved Temperature | | | | | | |
| Method Of Eliminating Agglomerate Particles In A Polishing Slurry | Taiwan | Granted | 2001-08-21 | 1999-03-29 | 87881-IN | 88104885 |
| Plate Capacitor Structure And Fabrication Method Therefor In A Dual Damascene Process | Taiwan | Lapsed | 2007-02-11 | 2003-09-17 | 1273702 | 92125649 |
| Silicon-Rich Low Thermal Budget Silicon Nitride For Integrated Circuits | Taiwan | Granted | 2009-10-11 | 2003-09-24 | 1315909 | 92126350 |
| Metal-Oxide-Semiconductor Device Formed in Silicon-On-Insulator | Taiwan | Lapsed | 2010-01-11 | 2004-06-09 | 1319598 | 093116604 |
| Methods and structure for IC temperature self-monitoring | United States of America | Lapsed | 2005-10-25 | 2003-02-18 | 6959258 | 10368520 |
| Method For Making An Integrated Circuit Including Alignment Marks | Taiwan | Lapsed | 2001-12-05 | 2000-02-16 | NI-138500 | 89100425 |
| Overlay Metrology Using Scatterometry Profiling | Taiwan | Lapsed | 2008-09-01 | 2003-04-14 | 1300584 | 92108572 |
| Heterojunction Bipolar Transistor | Taiwan | Granted | 2004-01-01 | 2002-01-08 | NI-193273 | 091100151 |
| Structures | Taiwan | Lapsed | 2003-07-01 | 2001-08-30 | NI-180535 | 90121457 |
| | | - | | | | |
| Field Plated Resistor With Enhanced Routing Area Thereover | Taiwan | Lapsed | 2003-11-01 | 2001-08-29 | NI-189135 | 090121356 |
| Local Area Alloying For Preventing Dishing Of Copper During Chemical Mechannical Polishing (CMP) | Taiwan | Lapsed | 2003-03-18 | 2001-04-11 | NI-166224 | 90108664 |
| Apparatus And Method For Continuous Delivery And Conditioning Of A Polishing Slurry | Taiwan | Granted | 2001-12-11 | 2000-03-31 | 276571-IN | 89106001 |
| Semiconductor Device Free Of LDD Regions | Taiwan | Granted | 2004-06-21 | 2000-06-29 | NI-204341 | 89112388 |
| Calcium doped polysilicon gate electrodes | United States of America | Lapsed | 2005-08-16 | 2003-10-30 | 6930362 | 10698167 |
| A Semiconductor Device Barrier Layer | Taiwan | Granted | 2004-03-04 | 2002-08-20 | 210061-IN | 91118815 |
| Improved Wehnelt Gun For Electron Lithography | Taiwan | Lapsed | 2002-08-01 | 2000-07-15 | 862651-IN | 89108684 |
| Capacitor For A Semiconductor Device And Method For Fabrication Therefor | Taiwan | Lapsed | 2007-04-21 | 2003-05-30 | 1279888 | 92114785 |
| A Process For Fabricating Integrated Circuit Devices Having Thin Film Transistors | Taiwan | Lapsed | 2002-03-11 | 2000-12-04 | NI-151729 | 89125762 |
| Daisy chain gang testing | United States of America | Granted | 2005-05-17 | 2003-10-23 | 6894524 | 10693078 |
| Methods For Fabricating A Multilevel Interconnection For An Integrated Circuit Device Utilizing A Selective Overlayer | United States of America | Granted | 2001-12-11 | 1999-12-03 | 1826289 | 09454909 |
| Article Comprising A Dielectric Material Of Zr-Ge-Ti-O Or Hf-Ge-Ti-O And Method Of Making The Same | United States of America | Granted | 2002-08-20 | 1999-12-08 | 6437392 | 09456807 |
| Method Of Manufacturing Lateral High-Q Inductor For Semiconductor Devices | United States of America | Granted | 2001-02-13 | 1999-10-12 | 6187647 | 09416336 |
| Method and apparatus for reducing microtrenching for borderless vias created in a dual damascene process | United States of America | Granted | 2004-09-21 | 2003-07-31 | 6794304 | 10631528 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Local Area Alloying For Preventing Dishing Of Copper During Chemical Mechannical Polishing (CMP) | Japan | Lapsed | 2010-07-16 | 2001-04-11 | 4548759 | 2001112078 |
|--|--------------------------|---------|------------|------------|------------|---------------|
| Thick Oxide Region In A Semiconductor Device | Korea, Republic of (KR) | Granted | 2012-11-23 | 2005-09-29 | 10-1206628 | 20050090978 |
| Inductor Formed In An Integrated Circuit | Korea, Republic of (KR) | Granted | 2011-06-23 | 2004-09-30 | 10-1045195 | 1020040078024 |
| Methods And Apparatus For Testing Integrated Circuits | Korea, Republic of (KR) | Lapsed | 2007-02-21 | 2000-08-01 | 687979 | 20000044542 |
| Integrated Circuit With Twin Tub | Korea, Republic of (KR) | Lapsed | 2006-02-16 | 1997-12-31 | 554648 | 9781732 |
| Silicon IC Contacts Using Composite TiN Barrier Layer | Korea, Republic of (KR) | Lapsed | 2001-06-05 | 1998-09-28 | 298970 | 9840192 |
| Interconnect | Korea, Republic of (KR) | Lapsed | 2001-08-21 | 1999-01-28 | 307421 | 1019990002654 |
| Device And Method Of Fabricating Vias For ULSI Metallization And | | | | | | |
| Deep Sub-Micron Metal Etch With In-Situ Hard Mask Etch | Korea, Republic of (KR) | Granted | 2007-05-03 | 1999-12-16 | 716436 | 1019990058177 |
| Method For Making Dual-Polysilicon Structures In Integrated Circuits | Korea, Republic of (KR) | Lapsed | 2007-04-03 | 1999-08-26 | 705308 | 1019990035568 |
| Electrochemical Abatement Of Perfluorinated Compounds | Korea, Republic of (KR) | Lapsed | 2004-02-25 | 2000-08-11 | 421757 | 1020000046601 |
| Method Of Manufacturing An Integrated Circuit Using A Scanning System And A Scanning System | Korea, Republic of (KR) | Lapsed | 2006-07-03 | 1999-10-26 | 598471 | 1019990046565 |
| Semiconductor Substrate And Process Of Making The Device | Korea, Republic of (KR) | Granted | 2004-11-02 | 2000-08-31 | 456705 | 20000051024 |
| Semiconductor Device Having Regions Of Insulating Material Formed In A | | | | | | |
| Alternating aperture phase-shift mask fabrication method | United States of America | Lapsed | 2006-01-17 | 2003-02-04 | 6986972 | 10358968 |
| Semiconductor Structure | Korea, Republic of (KR) | Lapsed | 2004-06-17 | 2000-12-06 | 0437743 | 20000073674 |
| A Method Of Forming An Alignment Feature In Or On A Multi-Layered | | | | | | |
| Article Comprising An Oxide Layer On GaN | Korea, Republic of (KR) | Lapsed | 2005-09-06 | 1998-10-09 | 516252 | 9842256 |
| Electronic Apparatus | Korea, Republic of (KR) | Granted | 2002-01-29 | 1999-02-05 | 0324072 | 1019990003869 |
| Process For Fabricating Vertical Transistors | Korea, Republic of (KR) | Lapsed | 2003-07-09 | 2000-06-16 | 392278 | 1020000033163 |
| Method Of Eliminating Agglomerate Particles In A Polishing Slurry | Korea, Republic of (KR) | Lapsed | 2002-04-24 | 1999-05-19 | 335703 | 19990017990 |
| Damascene Capacitors For Integrated Circuits | Korea, Republic of (KR) | Lapsed | 2007-03-08 | 2000-05-12 | 695028 | 1020000025275 |
| Interconnects | Korea, Republic of (KR) | Lapsed | 2007-04-19 | 1999-08-25 | 711526 | 1019990035378 |
| Process For Semiconductor Device Fabrication Having Copper | | | | | | |
| Improved Wehnelt Gun For Electron Lithography | Korea, Republic of (KR) | Lapsed | 2008-07-29 | 2000-05-08 | 850034 | 1020000024335 |
| Structures | Korea, Republic of (KR) | Lapsed | 2008-08-14 | 2001-08-31 | 853360 | 1020010053414 |
| Low K Dielectric Insulator and Method of Forming Semiconductor Circuit | | | | | | |
| Inductor Formed In An Integrated Circuit | Taiwan | Lapsed | 2012-04-11 | 2004-09-29 | 1362098 | 93129464 |
| Field Plated Resistor With Enhanced Routing Area Thereover | Korea, Republic of (KR) | Granted | 2008-11-19 | 2001-08-30 | 10-870256 | 1020010052999 |
| A Method Therefor | Korea, Republic of (KR) | Lapsed | 2008-09-29 | 2001-08-31 | 10-861665 | 1020010053350 |
| An Integrated Circuit Including ESD Circuits For A Multi-Chip Module And | | | | | | |
| Split-Gate Metal-Oxide-Semiconductor Device | Taiwan | Lapsed | 2010-05-21 | 2004-05-07 | 1325158 | 093113007 |
| A Method Of Forming A Multi-Layered Dual-Polysilicon Structure | Taiwan | Lapsed | 2002-01-11 | 2000-04-19 | NI-148715 | 89107369 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Deuterated Dielectric And Polysilicon Film-Based Semiconductor Devices And Method Of Manufacture Thereof | Japan | Granted | 2005-11-04 | 1998-04-16 | 3737277 | 10106377 |
|--|--------------------------|---------|------------|------------|------------|---------------|
| Process for forming planarized isolation trench in integrated circuit structure on semiconductor substrate | United States of America | Granted | 2003-08-19 | 2000-11-15 | 6607967 | 09714000 |
| Semiconductor Device | Japan | Lapsed | 2000-04-28 | 1999-01-13 | 3062485 | 11005911 |
| Scanning Electron Microscope System And Method Of Manufacturing An Integrated Circuit | Japan | Lapsed | 2005-09-16 | 1998-10-26 | 3720201 | 10303471 |
| Article Comprising An Oxide Layer On GaN | Taiwan | Lapsed | 2001-10-21 | 1998-08-19 | NI-143565 | 87113667 |
| Method For Making Dual-Polysilicon Structures In Integrated Circuits | Taiwan | Lapsed | 2002-03-01 | 1999-08-26 | NI-151235 | 88114626 |
| Method Of Manufacturing An Integrated Circuit Using A Scanning System And A Scanning System | Taiwan | Lapsed | 2001-04-01 | 1999-10-26 | NI-129146 | 88118471 |
| Apparatus For Processing Silicon Device With Improved Temperature Control | Japan | Lapsed | 2004-04-30 | 1999-05-17 | 3550315 | 11135599 |
| Article Comprising An Oxide Layer On GaN | Japan | Lapsed | 2000-01-14 | 1998-10-08 | 3023090 | 10287056 |
| Method For Making An Integrated Circuit Capacitor Including Tantalum Pentoxide | Taiwan | Lapsed | 2002-03-06 | 2000-01-06 | NI-144336 | 89100157 |
| Abnormal Photoresist Line/Space Profile Detection Through Signal Processing of Metrology Waveform | Taiwan | Lapsed | 2007-04-21 | 2003-04-14 | 1279872 | 92108571 |
| A Method Of Forming An Alignment Feature In Or On A Multi-Layered Semiconductor Structure | Taiwan | Lapsed | 2002-10-01 | 2000-12-01 | NI-165332 | 89125642 |
| An Integrated Circuit Including ESD Circuits For A Multi-Chip Module And A Method Therefor | Taiwan | Lapsed | 2003-06-21 | 2001-08-24 | NI-179943 | 90120871 |
| Method For Making An Integrated Circuit Including Alignment Marks | Japan | Lapsed | 2004-07-30 | 2000-01-12 | 3581285 | 2000003096 |
| Titanium-Tantalum Barrier Layer Film And Method For Forming The Same | Japan | Granted | 2003-06-27 | 2000-05-24 | 3445557 | 2000152242 |
| Method Of Making An Article Comprising An Oxide Layer On A GaAs- Based Semiconductor Body | Japan | Lapsed | 2005-09-30 | 1999-09-17 | 3725742 | 11263647 |
| Abnormal Photoresist Line/Space Profile Detection Through Signal Processing of Metrology Waveform | Korea, Republic of (KR) | Granted | 2010-12-20 | 2003-05-24 | 10-1003958 | 1020030033218 |
| Tungsten Silicide Nitride As An Electrode For Tantalum Pentoxide Devices | Japan | Lapsed | 2009-07-24 | 1999-12-13 | 4347479 | 11353614 |
| Method and integrated circuit for capacitor measurement with digital readout | United States of America | Granted | 2005-05-24 | 2003-03-19 | 6897673 | 10392206 |
| Article Comprising A Dielectric Material Of Zr-Ge-Ti-O Or Hf-Ge-Ti-O And Method Of Making The Same | Japan | Lapsed | 2013-03-01 | 2000-12-08 | 5208335 | 2000373648 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|---------------|------------|------------|------------|---------|--------------------------|--|
| 08262805 | 3530319 | 1996-10-03 | 5 | Expired | Japan | Compensation Of The Temperature Coefficient Of The Dielectric Constant Of Barium Strontium Titanate |
| 11141016 | 3550316 | 1999-05-21 | 2004-04-30 | Lapsed | Japan | Method Of Eliminating Agglomerate Particles In A Polishing Slurry |
| 10171971 | 3878744 | 1998-06-19 | 2006-11-10 | Granted | Japan | MOS Image Sensor |
| 11160696 | 3655497 | 1999-06-08 | 2005-03-11 | Lapsed | Japan | Single Crystal Silicon On Polycrystalline Silicon Integrated Circuits |
| 11207606 | 3699301 | 1999-07-22 | 2005-07-15 | Lapsed | Japan | Apparatus and Method for Integrated Circuit With Variable Capacitor |
| 09283277 | 3153163 | 1997-10-16 | 2001-01-26 | Lapsed | neder | Integrated Circuit Device With Inductor Incorporated Therein |
| 09360176 | 3253908 | 1997-12-26 | 2001-11-22 | Granted | Japan | Integrated Circuit With Twin Tub |
| 94128975 | 1368258 | 2005-08-24 | 2012-07-11 | Lapsed | Taiwan | Guard Ring for Improved Matching |
| 20030041375 | 803489 | 2003-06-25 | 2008-02-04 | Lapsed | Korea, Republic of (KR) | Capacitor For A Semiconductor Device And Method For Fabrication Therefor |
| 1020010018579 | 857727 | 2001-04-09 | 2008-09-03 | Lapsed | Korea, Republic of (KR) | Interconnections To Copper IC's |
| 1019990056953 | 671722 | 1999-12-11 | 2007-01-15 | Lapsed | Korea, Republic of (KR) | Tungsten Silicide Nitride As An Electrode For Tantalum Pentoxide Devices |
| 19990039502 | 632613 | 1999-09-15 | 2006-09-28 | Lapsed | Korea, Republic of (KR) | Manufacture Of Mosfet Devices |
| 1019990017300 | 304031 | 1999-05-14 | 2001-07-18 | Lapsed | Korea, Republic of (KR) | Apparatus For Processing Silicon Device With Improved Temperature Control |
| 9834393 | 373819 | 1998-08-25 | 2003-02-13 | Lapsed | Korea, Republic of (KR) | THIN FILM CAPACITORS AND PROCESS FOR MAKING THEM |
| 9815164 | 0307339 | 1998-04-28 | 2001-08-20 | Lapsed | Korea, Republic of (KR) | Deuterated Dielectric And Polysilicon Film-Based Semiconductor Devices And Method Of Manufacture Thereof |
| 1019970060838 | 516245 | 1997-11-18 | 2005-09-06 | Lapsed | Korea, Republic of (KR) | Integrated Circuit Device With Inductor Incorporated Therein |
| 1020000021415 | 697963 | 2000-04-22 | 2007-03-15 | Lapsed | Korea, Republic of (KR) | A Method Of Forming A Multi-Layered Dual-Polysilicon Structure |
| 1020010040533 | 753788 | 2001-07-06 | 2007-08-24 | Lapsed | Korea, Republic of (KR) | Silicon-On-Insulator (SOI) Semiconductor Structure With Trench Including A Conductive Layer |
| 10676934 | 6838379 | 2003-09-30 | 2005-01-04 | Granted | United States of America | Process for reducing impurity levels, stress, and resistivity, and increasing grain size of copper filler in trenches and vias of integrated circuit structures to enhance electrical performance of copper filler |
| 20030031929 | 10-0977947 | 2003-05-20 | 2010-08-18 | Granted | Korea, Republic of (KR) | A Semiconductor Device Barrier Layer |
| 1020030067833 | 10-988446 | 2003-09-30 | 2010-10-12 | Lapsed | Korea, Republic of (KR) | Plate Capacitor Structure And Fabrication Method Therefor In A Dual Damascene Process |
| 20040076311 | 10-1099907 | 2004-09-23 | 2011-12-21 | Lapsed | Korea, Republic of (KR) | Metal-Oxide-Semiconductor Device Including A Buried Lightly-Doped Drain Region |
| 2003334485 | 5039267 | 2003-09-26 | 2012-07-13 | Lapsed | Japan | Plate Capacitor Structure And Fabrication Method Therefor In A Dual Damascene Process |
| 09580939 | 6527867 | 2000-05-30 | 2003-03-04 | Granted | United States of America | Method for enhancing anti-reflective coatings used in photolithography of electronic devices |

| Auticle Opposition Voltage Vertical Dealersmant Outs (VDO) Transisters | Japan | Lapsed | 2013-01-18 | 2002-09-20 | 5179693 | 7007777605 |
|---|--------------------------|-----------|------------|------------|------------------|---------------|
| Process For Fabricating A Semiconductor Device Having A Metal Oxide Or A Metal Silicate GateDielectric Layer | Japan | Lapsed | 2013-01-18 | 2001-08-17 | 5177924 | 2001247517 |
| Metal-Oxide-Semiconductor Device Including A Buried Lightly-Doped Drain Region | Japan | Lapsed | 2014-05-23 | 2004-09-27 | 5547361 | 2004278820 |
| Electron beam fault detection of semiconductor devices | United States of America | Granted | 2001-04-03 | 1998-06-02 | 6211517 | 09088801 |
| Integrated Circuit Structure Having Low Dielectric Constant Material and Having Silicon Oxynitride Caps Over Closely Spaced Apart Metal Lines | United States of America | Abandoned | | 2002-05-21 | | 10153011 |
| Thick Oxide Region In A Semiconductor Device | China | Lapsed | 2009-09-30 | 2005-06-17 | ZL200510078169.X | 200510078169X |
| Guard Ring for Improved Matching | China | Lapsed | 2012-05-30 | 2005-09-14 | ZL200510109643.0 | 2005101096430 |
| Guard Ring for Improved Matching | Japan | Lapsed | 2012-03-09 | 2005-09-14 | 4944414 | 2005266157 |
| Lithographic Process For Device Fabrication Using Dark-Field Illumination | Japan | Lapsed | 2003-01-10 | 2000-03-30 | 3387888 | 2000093711 |
| A Method Of Forming A Multi-Layered Dual-Polysilicon Structure | Japan | Granted | 2007-11-16 | 2000-04-21 | 4038530 | 2000120437 |
| Etch resistant shallow trench isolation in a semiconductor wafer | United States of America | Lapsed | 2003-07-01 | 2000-12-11 | 6586814 | 09735084 |
| Metal-Oxide-Semiconductor Device Formed in Silicon-On-Insulator | Japan | Lapsed | 2013-10-04 | 2004-11-18 | 5378635 | 2004333824 |
| Thick Oxide Region In A Semiconductor Device | Japan | Abandoned | | 2005-09-26 | | 2005277005 |
| Split-Gate Metal-Oxide-Semiconductor Device | Japan | Lapsed | 2011-07-29 | 2004-05-14 | 4791706 | 2004144248 |
| Abnormal Photoresist Line/Space Profile Detection Through Signal Processing of Metrology Waveform | Japan | Lapsed | 2012-04-06 | 2003-05-23 | 4964400 | 2003145567 |
| Method and apparatus for cleaning deposited films from the edge of a wafer | United States of America | Granted | 2005-01-04 | 2002-11-06 | 6837967 | 10290437 |
| Inductor Formed In An Integrated Circuit | Japan | Lapsed | 2012-03-16 | 2004-09-29 | 4948756 | 2004283352 |
| Chromeless phase shift mask | United States of America | Lapsed | 2006-02-28 | 2003-04-04 | 7005217 | 10406847 |
| Method of incorporating nitrogen into metal silicate based dielectrics by energized nitrogen ion beams | United States of America | Granted | 2005-03-08 | 2003-06-03 | 6864141 | 10453118 |
| Method For Producing Tapered Lines | Japan | Lapsed | 2004-04-30 | 1997-06-04 | 3550272 | 09146787 |
| Manufacture Of Mosfet Devices | Japan | Lapsed | 2006-02-24 | 1999-09-14 | 3774088 | 11260600 |
| Semiconductor Structure | Japan | Lapsed | 2011-05-27 | 2000-12-07 | 4749537 | 2000372411 |
| A Method Of Forming An Alignment Feature In Or On A Multi-Layered | zaban | Granted | 77-90-5007 | 77-C0-96T | 3464607 | 10140363 |
| Silicon IC Contacts Using Composite TiN Barrier Layer | Japan | Lapsed | 2003-01-10 | 1998-09-29 | 3386385 | 10275117 |
| Electronic Apparatus | Japan | Lapsed | 2000-06-30 | 1999-02-02 | 3084015 | 11024534 |
| Semiconductor Device Having Regions Of Insulating Material Formed In A Semiconductor Substrate And Process Of Making The Device | Japan | Lapsed | 2007-05-18 | 2000-09-01 | 3958506 | 2000265144 |
| | - Сини | Status | atediuesa | rijedbate | Fatellino | Αμρινο |

| 003095783 | 003067238 | | 993040732 | 013070594 | | 993036359 | | 983095977 | | 10106128 | 10135383 | 963069646 | | 973035785 | | 003000536 | | 10288410 | 10216425 | 09675109 | 10267810 | 10251082 | 10207607 | | 09108092 | 2002270858 | | 2006345124 | 2001261004 | AppNo |
|--|---|---------------------------|---|--|---------------------------|------------|---|----------------------|--|------------------------------|---|------------------------------|--|------------------------------------|---------------------------|------------|--|---|---|--|--------------------------------------|--|---|---|---|-------------|---|--|--|-----------|
| 60030386.1 | 60006751.3 | | 69942327.9 | 60127777.5 | | 69944270.2 | | 69842401.8 | | 6733829 | 7174281 | 69607715.9 | | 69729913.9 | | 60023573.4 | | 6707132 | 6569739 | 6472715 | 6784102 | 7149340 | 6764749 | | 6175124 | 4797185 | | 5579358 | 5176050 | PatentNo |
| 2000-10-30 | 2000-08-07 | | 1999-05-26 | 2001-08-20 | | 1999-05-10 | | 1998-11-24 | | 2002-03-19 | 2002-05-01 | 1996-09-25 | | 1997-05-27 | | 2000-01-06 | | 2002-11-05 | 2002-08-08 | 2000-09-28 | 2002-10-09 | 2002-09-20 | 2002-07-29 | | 1998-06-30 | 2002-09-18 | | 2006-12-22 | 2001-08-30 | FiledDate |
| 2006-08-30 | 2003-11-26 | | 2010-05-05 | 2007-04-11 | | 2012-06-20 | | 2011-09-07 | | 2004-05-11 | 2007-02-06 | 2000-04-12 | | 2004-07-21 | | 2005-11-02 | | 2004-03-16 | 2003-05-27 | 2002-10-29 | 2004-08-31 | 2006-12-12 | 2004-07-20 | | 2001-01-16 | 2011-08-12 | | 2014-07-18 | 2013-01-18 | 3333 |
| Lapsed | Lapsed | | Granted | Lapsed | | Granted | | Granted | | Granted | Granted | Expired | | Expired | | Granted | | Granted | Granted | Granted | Granted | Granted | Granted | | Granted | Lapsed | | Lapsed | Lapsed | Status |
| Germany (Federal Republic of) | of) | Germany (Federal Republic | Germany (Federal Republic of) | ot) | Germany (Federal Republic | of) | Germany (Federal Republic | of) | Germany (Federal Republic | United States of America | United States of America | of) | Germany (Federal Republic | of) | Germany (Federal Republic | of) | Germany (Federal Republic | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | | United States of America | Japan | | Japan | Japan | Country |
| Method For Making Field Effect Devices And Capacitors With Thin Film Dielectrics And Resulting Devices | Electrochemical Abatement Of Perfluorinated Compounds | | Single Crystal Silicon On Polycrystalline Silicon Integrated Circuits | Field Plated Resistor With Enhanced Routing Area Thereover | | Control | Apparatus For Processing Silicon Device With Improved Temperature | Mechanical Polishing | Method Of Manufacturing An Integrated Circuit Using Chemical | Anti-binding deposition ring | Method for analyzing manufacturing data | Of Barium Strontium Titanate | Compensation Of The Temperature Coefficient Of The Dielectric Constant | Method For Producing Tapered Lines | | Pentoxide | Method For Making An Integrated Circuit Capacitor Including Tantalum | High performance Si-Ge device module with CMOS technology | Method of reducing the effect of implantation damage to shallow trench isolation regions during the formation of variable thickness gate layers | Reduced soft error rate (SER) construction for integrated circuit structures | Laterally interconnecting structures | Mask defect analysis for both horizontal and vertical processing effects | a coupling layer between the photo resist and the ARC | Method to improve the resolution of a photolithography system by use of | Method and apparatus for a wafer level system | Transistors | Bipolar Junction Transistor Compatible With Vertical Replacement Gate | Shallow Trench Isolation Structures Shallow Trench Isolation Structures | Field Plated Resistor With Enhanced Routing Area Thereover | Title |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|----------------------|--------------------|------------|-----------------------|--------------------|---|---|
| 003049921 | 60020011.6 | 2000-06-13 | 1 | Granted | Germany (Federal Republic of) | An Integrated Circuit Having A Micromagnetic Device And Method Of Manufacture Therefor |
| 0020/707/ | 60001600 E | 30.00 | 2002 02 12 | | Germany (Federal Republic | Process For Fabricating Vertical Transistors |
| 993069186 | 69937217.8 | 1999-08-31 | 2007-10-03 | Lapsed | Germany (Federal Republic of) | Article Having Passive Self-Assembly Inductor |
| 983002049 | 69839597.2 | 1998-01-13 | 2008-06-11 | Granted | Germany (Federal Republic of) | Semiconductor Device |
| 983045238 | 69804380.4 | 1998-06-09 | 2002-03-27 | Granted | Germany (Federal Republic of) | MOS Image Sensor |
| 003055078 | 7 V 350000 | 1999_07_17 | 2001_12_19 | Granted | Germany (Federal Republic | Apparatus and Method for Integrated Circuit With Variable Canacitor |
| | | 1,000 | 1001 | Ciairca | Germany (Federal Republic | 0 |
| 983079286 | 69823450.2 | 1998-09-29 | 2004-04-28 | Lapsed | of) | Article Comprising An Oxide Layer On GaN |
| 10242165 | 6842042 | 2002-09-11 | 2005-01-11 | Lapsed | United States of America | Global chip interconnect |
| 09792321 | 6458508 | 2001-02-23 | 2002-10-01 | Granted | United States of America | Method of protecting acid-catalyzed photoresist from chip-generated basic contaminants |
| 003105228 | 60039220.1 | 2000-11-27 | 2008-06-18 | Granted | Germany (Federal Republic of) | Article Comprising A Dielectric Material Of Zr-Ge-Ti-O Or Hf-Ge-Ti-O And Method Of Making The Same |
| 10036621 | 6935933 | 2001-12-21 | 2005-08-30 | Lapsed | United States of America | Viscous electropolishing system |
| 003023272 | 60030024.2 | 2000-03-22 | 2006-08-16 | Lapsed | Germany (Federal Republic of) | Lithographic Process For Device Fabrication Using Dark-Field Illumination |
| 003037868 | 60042468.5 | 2000-05-05 | 2009-07-01 | Granted | Germany (Federal Republic of) | Improved Wehnelt Gun For Electron Lithography |
| 10060002 | 6710851 | 2002-01-29 | 2004-03-23 | Granted | United States of America | Multi pattern reticle |
| 10067299 09213948 | 6621134 6528389 | 2002-02-07 | 2003-09-16 2003-03-04 | Granted Granted | United States of America United States of America | Vacuum sealed RF/microwave microresonator Substrate planarization with a chemical mechanical polishing stop layer |
| 09964157 | 6621146 | 2001-09-26 | 2003-09-16 | Granted | United States of America | Method and apparatus for the use of embedded resistance to linearize and improve the matching properties of transistors |
| 09209855 | 6303899 | 1998-12-11 | 2001-10-16 | Granted | United States of America | Method and apparatus for scribing a code in an inactive outer clear out area of a semiconductor wafer |
| 09974251 | 6513376 | 2001-10-10 | 2003-02-04 | Lapsed | United States of America | Liquid level height measurement system |
| 09994083 | 6549062 | 2001-11-21 | 2003-04-15 | Granted | United States of America | Method and apparatus for improving the tolerance of integrated resistors |
| 09974008 | 6658361 | 2001-10-10 | 2003-12-02 | Lapsed | United States of America | Heaviest only fail potential |
| 10615558 | 6989331 | 2003-07-08 | 2006-01-24 | Granted | United States of America | Hard mask removal |

| 10158641 68 | 09706286 65 | 09521312 64 | 10280394 34 | 1019980007413 58 | 09553140 77 | 09395062 62 | 09543412 63 | 08610026 58 | 08961383 61 | 983015629 69 | 1019980041563 36 | 08610646 56 | 08857079 57 | 08697402 57 | 09404702 62 | 07719699 57 | 08156953 59 | 07866942 56 | 08853210 59 | 08931066 58 | 2005060155 42 | 08746184 59 | | 200756483 | AppNo Pa |
|---|---|---|--|---|---|--|--|---|----------------------------|---|--|---|--|---|---------------------------------|---|--------------------------|--------------------------|---|--|------------------|--------------------------|--|--|-----------|
| 6864563 | 6544807 | 6413881 | 3481469 | 588369 | 7751609 | 6288453 | 6346490 | 5834800 | 6106371 | 69800033.1 | 364338 | 5620907 | 5798300 | 5728421 | 6239035 | 5744403 | 5982034 | 5679589 | 5918116 | 5804460 | 4276194 | 5976637 | | | PatentNo |
| 2002-05-30 | 2000-11-03 | 2000-03-09 | 1998-10-02 | 1998-03-06 | 2000-04-20 | 1999-09-13 | 2000-04-05 | 1996-03-04 | 1997-10-30 | 1998-03-03 | 1998-10-02 | 1996-03-04 | 1997-05-15 | 1996-08-23 | 1999-09-23 | 1991-06-25 | 1993-11-19 | 1992-04-03 | 1997-05-09 | 1997-09-15 | 1998-06-19 | 1996-11-06 | | 2007-03-07 | FiledDate |
| 2005-03-08 | 2003-04-08 | 2002-07-02 | 2003-10-10 | 2006-06-02 | 2010-07-06 | 2001-09-11 | 2002-02-12 | 1998-11-10 | 2000-08-22 | 1999-10-27 | 2002-11-28 | 1997-04-15 | 1998-08-25 | 1998-03-17 | 2001-05-29 | 1998-04-28 | 1999-11-09 | 1997-10-21 | 1999-06-29 | 1998-09-08 | 2009-03-13 | 1999-11-02 | | | GrantDate |
| Lapsed | Granted | Granted | Granted | Lapsed | Lapsed | Granted | Granted | Expired | Expired | Lapsed | Granted | Expired | Expired | Expired | Expired | Expired | Expired | Expired | Expired | Expired | Lapsed | Expired | | Abandoned | Status |
| United States of America | United States of America | United States of America | Japan | Korea, Republic of (KR) | United States of America | United States of America | United States of America | United States of America | United States of America | Germany (Federal Republic of) | Korea, Republic of (KR) | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Japan | United States of America | | Japan | Country |
| Grounding mechanism for semiconductor devices | Process monitor with statistically selected ring oscillator | Process for forming thin gate oxide with enhanced reliability by nitridation of upper surface of gate of oxide to form barrier of nitrogen atoms in upper surface region of gate oxide, and resulting product | Energy-Sensitive Resist Material And A Process For Device Fabrication UsingAn Energy-Sensitive Resist Material | Energy-Sensitive Resist Material And A Process For Device Fabrication Using An Energy-Sensitive Resist Material | A Method of Performing Oxide End-Point During CMP | Alignment of openings in semiconductor fabrication | Process for treating damaged surfaces of low k carbon doped silicon oxide dielectric material after plasma etching and plasma cleaning steps | A Heterojunction Bipolar Transistor Having Monocrystalline SiGe Intrinsic Base And Polycrystalline SiGe and Si Extrinsic Base Regions | Effective pad conditioning | Energy-Sensitive Resist Material And A Process For Device Fabrication Using An Energy-Sensitive Resist Material | Energy-Sensitive Resist Material And A Process For Device Fabrication UsingAn Energy-Sensitive Resist Material | Method For Making A Heterojunction Bipolar Transistor | Method For Forming Conductors In Integrated Circuits | Article Comprising Spinel-Structure Material On A Substrate, And Method Of Making The Article | Semiconductor Wafer Fabrication | Dielectric Film Deposition Method And Apparatus | Conductive Oxide Films | FET With Gate Spacer | Process For Forming Different Gate Oxides Possessing Different Thicknesses On A Semiconductor Substrate | Linewidth Metrology Of Integrated Circuit And Structures | MOS Image Sensor | Layers | Method For Coating Heterogeneous Substrates With Homogeneous | An Integrated Circuit Including ESD Circuits For A Multi-Chip Module And A Method Therefor | Title |

| lic Method and Apparatus for Protecting Functions Imbedded Within an Integrated Circuit from Reverse Engineering | Germany (Federal Republic of) | Expired | 2001-08-08 | 1997-03-26 | 69706043.8 | 979156007 |
|---|-------------------------------|---------|------------|------------|------------|------------|
| Variable Step Height Control of Lithographic Patterning Through Transmitted Light Intensity Variation | Taiwan | Lapsed | 2000-07-04 | 1997-12-13 | 112608 | 86118838 |
| Simple BiCMOS Process for Creation of Low Trigger Voltage SCR and Zener Diode Pad Protection | Taiwan | Lapsed | 2001-02-05 | 1997-12-17 | 120428 | 86119036 |
| Method and apparatus for detecting an ion-implanted polishing endpoint layer within a semiconductor wafer | United States of America | Granted | 2001-07-31 | 1998-06-30 | 6268224 | 09108091 |
| A Method and Apparatus for Chemical Mechanical Polishing | Taiwan | Lapsed | 2001-02-01 | 1998-09-23 | 120367 | 87115810 |
| Method for composing a thermally conductive thin film having a low dielectric property | United States of America | Granted | 2000-07-18 | 1998-12-15 | 6090724 | 09211922 |
| Fabrication of differential gate oxide thicknesses on a single integrated circuit chip | United States of America | Granted | 2001-05-22 | 1998-12-18 | 6235590 | 09216394 |
| Standardized Gas Isolation Box (GIB) Installation | Taiwan | Lapsed | 2002-02-08 | 1998-09-04 | 142684 | 87114682 |
| Method for manufacturing a metal-to-metal capacitor utilizing only one masking step | United States of America | Granted | 2001-08-28 | 1999-07-02 | 6281092 | 09347487 |
| Non-Linear Circuit Elements on Integrated Circuits | Germany (Federal Republic of) | Granted | 2008-05-15 | 1999-05-05 | 19920757.7 | 199207577 |
| Slurry Collecting Device for CMP Slurry Circulation | Japan | Lapsed | 2011-01-07 | 1999-12-10 | 4657412 | 1999351216 |
| Process for forming high dielectric constant gate dielectric for integrated circuit structure | United States of America | Granted | 2003-01-28 | 2001-10-19 | 6511925 | 10033164 |
| Apparatus and method for linearly planarizing a surface of a semiconductor wafer | United States of America | Granted | 2002-10-15 | 2000-06-29 | 6464566 | 09607177 |
| Process for Fabricating a Moderate-Depth Diffused Emitter Bipolar Transistor in a BICMOS Device Without Using an Additional Mask | Japan | Granted | 2009-10-09 | 1998-04-02 | 4386468 | 1998542006 |
| Multiple metal etchant system for integrated circuits | United States of America | Granted | 2002-09-10 | 2000-01-20 | 6448084 | 09487984 |
| Method and apparatus for using across wafer back pressure differentials to influence the performance of chemical mechanical polishing | United States of America | Granted | 2003-03-11 | 1998-01-09 | 6531397 | 09005364 |
| Process for forming metal silicide contacts using amorphization of exposed silicon while minimizing device degradation | United States of America | Expired | 2000-01-04 | 1997-01-23 | 6010952 | 08787992 |
| Process for forming low k silicon oxide dielectric material while suppressing pressure spiking and inhibiting increase in dielectric constant | United States of America | Granted | 2000-11-14 | 1999-11-12 | 6147012 | 09438642 |
| FETs having lightly doped drain regions that are shaped with counter and noncounter dorant elements | United States of America | Expired | 2001-01-30 | 1996-12-19 | 6180470 | 08770046 |
| Statistical decision system | United States of America | Granted | 2004-08-24 | 2000-08-15 | 6782500 | 09639440 |
| Interconnection system with lateral barrier layer | United States of America | Granted | 2002-07-30 | 2000-05-19 | 6426286 | 09574804 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Stress Migration Test Structure And Method Therefor | United States of America | Granted | 2004-06-08 | 2001-10-31 | 6747445 | 10007904 |
|--|--------------------------|---------|------------|------------|-----------|----------|
| Therefor | United States of America | Granted | 2004-01-27 | 2001-10-31 | 6683465 | 10007417 |
| Integrated Circuit Having Stress Migration Test Structure And Method | | | | | | |
| Semiconductor Device Using An Insulating Layer Having A Seed Layer | United States of America | Granted | 2004-11-30 | 2002-11-20 | 6825538 | 10300365 |
| Graded Conductive Structure For Use In A Metal\(miOxide\(miSemiconductor Device) | United States of America | Granted | 2006-12-12 | 2004-06-28 | 7148540 | 10878857 |
| Semiconductor Device Manufacturing | United States of America | Granted | 2007-03-27 | 2004-09-29 | 7197723 | 10953480 |
| Method to Improve Performance Of A Bipolar Device Using An Amorphizing Implant | United States of America | Granted | 2009-01-20 | 2006-08-31 | 7479438 | 11469032 |
| Hot-Electron Injection Testing Of Transistors On A Wafer | United States of America | Granted | 2011-03-01 | 2008-12-24 | 7898277 | 12344016 |
| High voltage tolerant thin film transistor | United States of America | Granted | 2000-07-25 | 1998-05-08 | 6093585 | 09075029 |
| Method for tungsten nucleation from WF6 using titanium as a reducing agent | United States of America | Expired | 1999-10-05 | 1996-12-23 | 5963828 | 08773471 |
| Variable step height control of lithographic patterning through transmitted light intensity variation | United States of America | Expired | 1998-10-13 | 1996-12-13 | 5821013 | 08763373 |
| Isolation method utilizing a high pressure oxidation | United States of America | Granted | 2000-06-06 | 1998-03-23 | 6071817 | 09046242 |
| Electrode assembly for plasma reactor | United States of America | Expired | 1999-11-02 | 1996-12-17 | 5976309 | 08767698 |
| Method for polishing a wafer | United States of America | Expired | 1997-07-08 | 1995-12-29 | 5645736 | 08580674 |
| Method of detecting a polishing endpoint layer of a semiconductor wafer which includes a non-reactive reporting specie | United States of America | Granted | 2000-06-27 | 1998-08-10 | 6080670 | 09131921 |
| Method and apparatus for detecting a polishing endpoint based upon infrared signals | United States of America | Granted | 2001-06-05 | 1998-06-30 | 6241847 | 09107342 |
| System and method for optimizing the electrostatic removal of a workpiece from a chuck | United States of America | Lapsed | 2005-05-24 | 2001-08-29 | 6898064 | 09942220 |
| Method of manufacturing semiconductor device having a recessed gate structure | United States of America | Granted | 2001-08-21 | 1998-12-16 | 6277707 | 09212931 |
| Process for Fabricating a Moderate-Depth Diffused Emitter Bipolar Transistor in a BICMOS Device Without Using an Additional Mask | Taiwan | Lapsed | 2000-12-05 | 1998-04-02 | 118316 | 87104961 |
| Method and Apparatus for Protecting Functions Imbedded Within an Integrated Circuit from Reverse Engineering | Taiwan | Lapsed | 1998-09-10 | 1997-05-03 | NI-094528 | 86105907 |
| High reliability bearing structure | United States of America | Granted | 2001-03-27 | 1998-05-21 | 6206573 | 09082810 |
| Apparatus for detecting an endpoint polishing layer of a semiconductor wafer having a wafer carrier with independent concentric sub-carriers and associated method | United States of America | Granted | 2001-09-04 | 1998-07-08 | 6285035 | 09111529 |
| Apparatus and method for detecting an endpoint of an etching process by transmitting infrared light signals through a semiconductor wafer | United States of America | Granted | 2001-01-16 | 1998-12-03 | 6174407 | 09204767 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 10963156 7179148 | 09338520 6815876 | 09399621 6281129 | 09376696 6206770 | 09430635 6136615 | 09482390 6401929 | 09459708 6537135 | 09603340 6372605 | 09520670 6611729 | 09397716 6251546 | 09611581 6435946 | 09737717 6551410 | 09640329 6362094 | 09648015 6367329 | 09653364 6569690 | 09653531 6630699 | 09731402 6896583 | 09964041 6737311 | 09935241 6548906 | 09865124 6541819 | Appino Patentino |
|--|---|---|---|---|--|---|--|---|---|--|---|--|---|--|--|---|--|---|---|------------------|
| | | | | | | | | | | | | | | | | | | | | |
| 2004-10-12 | 1999-06-23 | 1999-09-20 | 1999-08-18 | 1999-10-29 | 2000-01-12 | 1999-12-13 | 2000-06-26 | 2000-03-07 | 1999-09-16 | 2000-07-07 | 2000-12-15 | 2000-08-16 | 2000-08-25 | 2000-08-31 | 2000-08-31 | 2001-02-06 | 2001-09-26 | 2001-08-22 | 2001-05-24 | riiedDate |
| 2007-02-20 | 2004-11-09 | 2001-08-28 | 2001-03-27 | 2000-10-24 | 2002-06-11 | 2003-03-25 | 2002-04-16 | 2003-08-26 | 2001-06-26 | 2002-08-20 | 2003-04-22 | 2002-03-26 | 2002-04-09 | 2003-05-27 | 2003-10-07 | 2005-05-24 | 2004-05-18 | 2003-04-15 | 2003-04-01 | Grantbate |
| Granted | Lapsed | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Lapsed | Granted | Granted | Granted | Surerc |
| United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Country |
| Cathode With Improved Work Function And Method For Making The Same | Cathode With Improved Work Function And Method Of Making Same | Corrosion-Resistant Polishing Pad Conditioner | Wafer Carrier Head For Prevention Of Unintentional Semiconductor Wafer Rotation | Migration From Control Wafer To Product Wafer Particle Checks | Insert For Use In Transporting A Wafer Carrier | Curvilinear Chemical Mechanical Planarization Device And Method | Additional Etching To Decrease Polishing Time for Shallow-Trench Isolation In Semiconductor Processing | System And Method For Introducing Multiple Component-Type Factors Into An Integrated Circuit Yield Prediction | An Improved Method Of Fabricating Devices Using An Attenuated Phase- Shifting Mask And An Attenuated Phase-Shifting Mask | Technique For Reducing Slivers On Optical Components Resulting From Friction Processes | Method Of Cleaning A Semiconductor Wafer With A Cleaning Brush Assembly Having A Contractible An Expandable Arbor | Hydrogenated Silicon Carbide As A Liner For Self-Aligning Contact Vias | Acoustic Time Of Flight And Acoustic Resonance Methods For Detecting Endpoint In Plasma Processes | Monitoring System For Determining Progress In A Fabrication Activity | Transistor Device Having An Isolation Structure Located Under A Source Region, Drain Region And Channel Region And A Method Of Manufacture Thereof | Method And Apparatus For Conditioning A Polishing Pad | Semiconductor Device Having A Buried Layer For Reducing Latchup And A Method Of Manufacture Therefor | Method For Reducing A Metal Seam In An Interconnect Structure And A Device Manufactured Thereby | Semiconductor Device Having Non\{miPower Enhanced And Power Enhanced Metal Oxide Semiconductor And Method Of Manufacture Therefor | |

| Doping Of Silicon Layers | United States of America | Expired | 1998-01-27 | 1995-06-30 | 5712176 | 08497470 |
|--|-------------------------------|-----------|------------|------------|------------|-------------|
| | United States of America | Expired | 1996-12-31 | 1995-03-29 | 5588969 | 08412678 |
| Methof Of Forming A DMOS-Controlled Lateral Bipolar Transistor | United States of America | Expired | 1997-09-23 | 1995-11-21 | 5670396 | 08561473 |
| Method Of Determining The Thermal Conductivity Of Electrically Insulating Crystalline Materials | United States of America | Expired | 1997-04-15 | 1995-07-31 | 5620253 | 08509678 |
| Cassette Light | United States of America | Expired | 1999-01-05 | 1995-12-14 | 5855280 | 08572599 |
| Method Of Making A Low Noise Semiconductor Device Comprising A Screening Measurement | United States of America | Expired | 1997-11-04 | 1996-07-03 | 5683917 | 08674956 |
| Thin Film Metallization For Barium Nanotitanate Substrates | United States of America | Expired | 1998-07-14 | 1996-10-07 | 5779929 | 08727726 |
| Method Of Integrated Circuit Fabrication | United States of America | Expired | 2000-01-11 | 1997-09-05 | 6013556 | 08924728 |
| Optical Monitoring System For III\(mi\) Wafer Processing | United States of America | Granted | 2000-06-13 | 1998-06-26 | 6075909 | 09105712 |
| Article Comprising A Stable, Low-Resistance Ohmic Contact | United States of America | Granted | 2001-04-24 | 1998-01-31 | 6222863 | 09017103 |
| Temperature Compensation of LDMOS Devices | United States of America | Granted | 2000-07-18 | 1998-04-13 | 6091279 | 09058826 |
| Elements And Devices Employing Same | United States of America | Granted | 2000-07-25 | 1998-06-04 | 6093944 | 09090295 |
| Dielectric Materials Of Amorphous Compositions of Ti\(mi 02 Doped With Rare Earth | | | | | | |
| Integrated Circuit Fabrication | United States of America | Expired | 2002-05-07 | 1998-02-17 | 6384446 | 09024601 |
| Vertical PNP Bipolar Transistor And Its Method Of Fabrication | United States of America | Granted | 2002-03-19 | 1998-12-28 | 6359317 | 09222587 |
| Method For Removing Contaminants From Integrated Circuits | United States of America | Granted | 2000-12-19 | 1999-01-15 | 6162733 | 09232120 |
| Method For Manufacturing Semiconductor Integrated Circuits With Etch Process Modification | United States of America | Abandoned | | 1999-07-02 | | 09346754 |
| Method Analyzing A Semiconductor Surface Using Line Width Metrology With Auto-Correlation Operation | United States of America | Granted | 2001-07-10 | 1999-07-02 | 6258610 | 09347313 |
| Process For Fabricating An Integrated Circuit Device Having Capacitors With A Multilevel Metallization | United States of America | Granted | 2003-05-06 | 2000-01-04 | 6559499 | 09477310 |
| Cathode With Improved Work Function And Method Of Making Same | United Kingdom | Lapsed | 2010-04-14 | 2000-06-13 | 1063669 | 003050150 |
| Cathode With Improved Work Function And Method Of Making Same | France | Lapsed | 2010-04-14 | 2000-06-13 | 1063669 | 003050150 |
| Cathode With Improved Work Function And Method Of Making Same | Korea, Republic of (KR) | Lapsed | 2007-07-25 | 2000-06-22 | 744896 | 20000034530 |
| Cathode With Improved Work Function And Method Of Making Same | Germany (Federal Republic of) | Granted | 2010-04-14 | 2000-06-13 | 60044167.9 | 003050150 |
| Cathode With Improved Work Function And Method Of Making Same | Taiwan | Lapsed | 2001-09-11 | 2000-06-19 | NI-141143 | 89111997 |
| Cathode With Improved Work Function And Method Of Making Same | Japan | Lapsed | 2007-01-12 | 2000-06-23 | 3901915 | 2000188555 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Controlling Overspray Coating In Semiconductor Devices | United Kingdom | Lapsed | 2010-08-10 | 2006-09-07 | 2431042 | 06175889 |
|---|--------------------------|-------------|------------|------------|------------------|---------------|
| Controlling Overspray Coating In Semiconductor Devices | Korea, Republic of (KR) | Granted | 2014-01-22 | 2006-09-21 | 10-1356667 | 1020060091668 |
| Controlling Overspray Coating In Semiconductor Devices | Japan | Granted | 2013-05-24 | 2006-09-21 | 5275558 | 2006255124 |
| Area-Efficient Power Switching Cell | United States of America | Lapsed | 2010-05-04 | 2005-12-29 | 7712066 | 11322103 |
| Dielectric Etching | United States of America | Lapsed | 2012-11-27 | 2009-08-25 | 8318606 | 12546855 |
| Defectivity-Immune Technique of Implementing MiM-based Decoupling Capacitors | European Patent | Abandoned | | 2011-07-19 | | 111745519 |
| Defectivity-Immune Technique of Implementing MiM-based Decoupling Capacitors | Korea, Republic of (KR) | Lapsed | 2014-05-09 | 2011-07-14 | 10-1395584 | 1020110069793 |
| Defectivity-Immune Technique of Implementing MiM-based Decoupling Capacitors | United States of America | Granted | 2013-04-02 | 2010-07-19 | 8411399 | 12839148 |
| Defectivity-Immune Technique of Implementing MiM-based Decoupling Capacitors | Japan | Lapsed | 2014-06-27 | 2011-07-19 | 5566346 | 2011157508 |
| Defectivity-Immune Technique of Implementing MiM-based Decoupling Capacitors | China | Lapsed | 2015-04-08 | 2011-07-15 | ZL2011101979218 | 2011101979218 |
| Defectivity-Immune Technique of Implementing MiM-based Decoupling Capacitors | Taiwan | Lapsed | 2013-07-21 | 2011-06-20 | 1402965 | 100121509 |
| Method And Apparatus For Performing Metalization In An Integrated Circuit Process | United States of America | Granted | 2009-10-20 | 2006-12-12 | 7607112 | 11609509 |
| Virtual-Ground, Split Gate Flash Memory Cell Arrangements and Method For Producing Same | United States of America | Granted | 2003-02-11 | 2000-12-19 | 6518619 | 09741667 |
| High Voltage Tolerant Metal-Oxide-Semiconductor Device | United States of America | Granted | 2012-01-31 | 2011-05-31 | 8105912 | 13149122 |
| High Voltage Tolerant Metal-Oxide-Semiconductor Device | United States of America | Granted | 2011-07-12 | 2008-04-30 | 7977721 | 12112076 |
| Material Removing Processes In Device Formation And The Devices Formed Thereby | United States of America | Granted | 2011-07-05 | 2008-10-27 | 7972873 | 12290054 |
| An Electronic Pressure-Sensing Device | China | Lapsed | 2014-07-02 | 2010-05-12 | ZL201010178744.4 | 2010101787444 |
| An Electronic Pressure-Sensing Device | European Patent | Application | | 2010-05-13 | | 101627768 |
| An Electronic Pressure-Sensing Device | Korea, Republic of (KR) | Lapsed | 2015-04-09 | 2010-05-07 | 101512527 | 1020100042858 |
| Electronic Pressure-Sensing Device | United States of America | Granted | 2011-10-18 | 2009-05-13 | 8037771 | 12465309 |
| An Electronic Pressure-Sensing Device | Japan | Granted | 2016-02-19 | 2010-05-12 | 5885909 | 2010109863 |
| An Electronic Pressure-Sensing Device | Taiwan | Granted | 2014-01-21 | 2010-04-27 | 1424152 | 099113363 |
| Two-Layer Type Programmable Resistor | Japan | Lapsed | 2007-06-22 | 1997-12-12 | 3973744 | 97342851 |
| same | United States of America | Expired | 1999-03-16 | 1998-04-03 | 5882998 | 09055018 |
| Low power programmable fuse structures and methods for making the | | | | | | |
| Low Power Programmable Fuse Structures | United States of America | Expired | 1998-12-29 | 1997-06-26 | 5854510 | 08883403 |
| Method for Bi-Layer Programmable Resistor | United States of America | Expired | 1999-11-02 | 1996-12-27 | 5976943 | 08774036 |
| Method Comprising Removal Of Material From A Diamond Film | United States of America | Granted | 2001-03-06 | 1994-07-21 | 6197375 | 08278688 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|-----------|----------|------------|------------|-----------|--------------------------|--|
| 095134838 | 1437785 | 2006-09-20 | 2014-05-11 | Granted | Taiwan | Controlling Overspray Coating In Semiconductor Devices |
| 11232074 | 7269197 | 2005-09-21 | 2007-09-11 | Granted | United States of America | Controlling Overspray Coating In Semiconductor Devices |
| 12680017 | | 2010-03-25 | 2013-02-05 | Abandoned | United States of America | Method to Reduce Trench Capacitor Leakage For Random Access Memory Device |
| 11094975 | 7329605 | 2005-03-31 | 2008-02-12 | Granted | United States of America | Semiconductor Structure Formed Using A Sacrificial Structure |
| 11927978 | 7741702 | 2007-10-30 | 2010-06-22 | Granted | United States of America | Semiconductor Structure Formed Using A Sacrificial Structure |
| 11068237 | 7247556 | 2005-02-28 | 2007-07-24 | Granted | United States of America | Control Of Wafer Warpage During Backend Processing |
| | | | | | | Methods And Apparatus For Determining Location-Based On-Chip |
| 11124307 | 7399648 | 2005-05-06 | 2008-07-15 | Granted | United States of America | Variation Factor |
| 11673645 | 7557010 | 2007-02-12 | 2009-07-07 | Granted | United States of America | Method To Improve Writer Leakage in a SiGe Bipolar Device |
| 12476994 | 7898038 | 2009-06-02 | 2011-03-01 | Granted | United States of America | Method To Improve Writer Leakage in SiGe Bipolar Device |
| | | | | | | Apparatus And Method For In-Situ Measuring Of Vibrational Energy In A |
| 10902332 | 7111517 | 2004-07-29 | 2006-09-26 | Lapsed | United States of America | Process Bath Of A Vibrational Cleaning System |
| 10773614 | 7214568 | 2004-02-06 | 2007-05-08 | Granted | United States of America | Semiconductor Device Configured For Reducing Post-Fabrication Damage |
| 10778454 | 7005724 | 2004-02-13 | 2006-02-28 | Lapsed | United States of America | A Semiconductor Device And A Method Of Manufacture Therefor |
| 11167772 | 7811944 | 2005-06-27 | 2010-10-12 | Lapsed | United States of America | A Semiconductor Device And A Method Of Manufacture Therefor |
| | | | | | | Alternating Pulse Dual\(miBeam Apparatus, Methods And Systems For |
| 10675581 | 6906538 | 2003-09-30 | 2005-06-14 | | United States of America | Voltage Contrast Behavior Assessment of Microcircuits |
| 10919591 | 7339274 | 2004-08-17 | 2008-03-04 | Granted | United States of America | Metallization Performance In Electronic Devices |
| 10695193 | 6975040 | 2003-10-28 | 2005-12-13 | Lapsed | United States of America | Fabricating Semiconductor Chips |
| 10999704 | 7262476 | 2004-11-30 | 2007-08-28 | Granted | United States of America | Semiconductor Device Having Improved Power Density |
| 10981175 | 7573097 | 2004-11-03 | 2009-08-11 | Lapsed | United States of America | Lateral Double Diffused MOS Transistors |
| 10200233 | 6838213 | 2002-07-23 | 2005-01-04 | Granted | United States of America | Process For Fabricating A Mask |
| 09882624 | 6958518 | 2001-06-15 | 2005-10-25 | Lapsed | United States of America | A Semiconductor Device Having At Least One Source\(sIDrain Region Formed On An Isolation Region And A Method Of Manufacture Therefor |
| 09943630 | 6648734 | 2001-08-30 | 2003-11-18 | Granted | United States of America | Polishing Head For Pressurized Delivery Of Slurry |
| 10008015 | 6703712 | 2001-11-13 | 2004-03-09 | Granted | United States of America | Microelectronic Device Layer Deposited With Multiple Electrolytes |
| 09859316 | 6433628 | 2001-05-17 | 2002-08-13 | Granted | United States of America | Wafer Testable Integrated Circuit |
| 09882623 | 6569744 | 2001-06-15 | 2003-05-27 | Granted | United States of America | Method Of Converting A Metal Oxide Semiconductor Transistor Into A Bipolar Transistor |
| 09927752 | 6503793 | 2001-08-10 | 2003-01-07 | Granted | United States of America | Method For Concurrently Forming An ESD Protection Device And A Shallow Trench Isolation Region |
| 10180221 | 6825467 | 2002-06-25 | 2004-11-30 | Granted | United States of America | Apparatus For Scanning A Crystalline Sample And Associated Methods |
| 10274765 | 6723581 | 2002-10-21 | 2004-04-20 | Granted | United States of America | Semiconductor Device Having A High-K Gate Dielectric And Method Of Manufacture Thereof |

| Use Of Small Openings In Large Topography Features To Improve Dielectric Thickness Control And A Method Of Manufacture Thereof | United States of America | Granted | 2003-04-29 | 2000-08-29 | 6555910 | 09651661 |
|--|--------------------------|---------|------------|------------|-----------|-----------|
| Method For Avoiding Notching In A Semiconductor Interconnect During A Metal Etching Step | United States of America | Granted | 2003-05-06 | 2000-11-15 | 6559062 | 09713504 |
| Method For Cleaning Tungsten From Deposition Wall Chambers | United States of America | Lapsed | 2003-07-01 | 2000-11-30 | 6585830 | 09727326 |
| Direct Drive Spindle For Use In Chemical Vapor Deposition | United States of America | Granted | 2002-03-19 | 2000-04-04 | 6359400 | 09542362 |
| Improved Substrate Isolation For Analog\(sIDigital IC Chips | United States of America | Granted | 2003-02-25 | 2000-08-03 | 6525394 | 09631862 |
| Method And Apparatus For Controlling Contamination During The Electroplating Deposition Of Metals Onto A Semiconductor Wafer Surface | United States of America | Granted | 2003-06-03 | 2001-09-28 | 6573183 | 09965739 |
| Calibration Standard For High Resolution Electron Microscopy | United States of America | Lapsed | 2004-06-15 | 2002-04-12 | 6750447 | 10122645 |
| Integrated Circuits with Tub-Ties and Shallow Trench Isolation | United States of America | Granted | 2002-03-19 | 2000-11-03 | 6358824 | 09706319 |
| Method And Apparatus For Minimizing Semiconductor Wafer Contamination | United States of America | Granted | 2004-02-24 | 2001-09-28 | 6695572 | 09966156 |
| Anistropic Wet Etching Method | United States of America | Granted | 2002-11-26 | 2000-04-27 | 6486075 | 09559494 |
| Method Of Forming A Semiconductor Device | United States of America | Granted | 2004-03-16 | 2001-02-23 | 6706603 | 09792266 |
| Dual Level Gate Process For Hot Carrier Control In Double Diffused MOS Transistors | United States of America | Granted | 2003-05-06 | 2000-10-19 | 6559011 | 09692012 |
| Two Phase Chemical\(sIMechanical Polishing Process For Tungsten Layers | United States of America | Granted | 2002-08-20 | 2000-08-04 | 6436829 | 09632445 |
| Formation Of Silicon On Insulator (SOI) Devices As An Add On Module For System On A Chip (SOC) Processing | Taiwan | Lapsed | 2003-08-11 | 2002-06-17 | NI-183665 | 091113153 |
| Formation Of Silicon On Insulator (SOI) Devices As An Add On Module For System On A Chip (SOC) Processing | United Kingdom | Lapsed | 2006-01-25 | 2002-06-17 | 2381378 | 02138634 |
| Formation Of Silicon On Insulator (SOI) Devices As An Add On Module For System On A Chip (SOC) Processing | United States of America | Granted | 2003-08-05 | 2001-06-15 | 6602758 | 09882961 |
| Pad For Chemical Mechanical Polishing | United States of America | Granted | 2003-12-09 | 2001-09-17 | 6659846 | 09954341 |
| Technique For Reducing Dishing In Cu-Based Interconnects | United States of America | Granted | 2001-11-20 | 2000-06-29 | 6319837 | 09606833 |
| A Semiconductor Device | United States of America | Granted | 2003-10-28 | 2000-11-15 | 6639285 | 09713106 |
| Method Of Manufacturing A Semiconductor Device Employing A Fluorine- Based Etch Substantially Free Of Hydrogen | United States of America | Granted | 2003-06-10 | 2001-10-26 | 6576563 | 10047516 |
| Semiconductor Device Having An Interconnect That Electrically Connects A Conductive Material And A Doped Layer, And A Method Of Manufacture Therefor | United States of America | Lapsed | 2004-12-07 | 2002-05-07 | 6828649 | 10140616 |
| Alignment Mark Fabrication Process To Limit Accumulation Of Errors In Level To Level Overlay | United States of America | Granted | 2002-08-27 | 2001-01-30 | 6440816 | 09771621 |
| Method And Apparatus For Detection Of Chemical Mechanical Planarization Endpoint And Device Planarity | United States of America | Granted | 2004-08-31 | 2002-04-10 | 6783426 | 10120767 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Non\\miHvdrolytic Sol\\miGel Process For High K Dielectric | United States of America | Lapsed | 2003-09-09 | 2000-03-23 | 6616965 | 06233/100 |
|---|--------------------------|---------|---------------|--|---------|-----------|
| Apparatus And Method For In-Situ Measurement Of Polishing Pad Thickness Loss | United States of America | Granted | 2002-03-12 | 2000-01-31 | 6354910 | 09494705 |
| A Process For Improving Line Width Variations Between Tightly Spaced And Isolated Features In Integrated Circuits | United States of America | Granted | 2002-05-28 | 1999-09-16 | 6395639 | 09397458 |
| A Semicondutor Device Having Reduced Line Width Variations Between Tightly Spaced And Isolated Features | United States of America | Granted | 2002-06-18 | 1999-09-16 | 6406999 | 09397459 |
| Apparatus And Method For Enhanced Dielectric Film Uniformity | United States of America | Granted | 2000-12-05 | 1999-09-28 | 6156675 | 09407575 |
| A Distributed Communications System For Reducing Equipment Down-Time | United States of America | Granted | 2001-06-12 | 1999-11-18 | 6246325 | 09442688 |
| Apparatus For Measuring Thermomechanical Properties Of Photo\(miSensitive Materials | United States of America | Granted | 2003-01-28 | 1999-10-19 | 6511221 | 09420234 |
| Method For Detecting Defects In A Material And A System For Accomplishing The Same | United States of America | Granted | 2005-03-22 | 2001-03-15 | 6870950 | 09809379 |
| Glove Box Filter System | United States of America | Granted | 2001-05-22 | 1999-08-25 | 6235072 | 09382611 |
| Apparatus For Detecting Wetness Of A Semiconductor Wafer Cleaning Brush | United States of America | Granted | 2003-09-09 | 2001-03-29 | 6615433 | 09821506 |
| Integrated Circuit Fabrication | United States of America | Granted | 2003-03-25 | 2000-11-30 | 6537887 | 09727325 |
| Method For Making A Bipolar Transistor With An Oxygen Implanted Emitter Window | United States of America | Granted | 2004-11-09 | 2001-12-21 | 6815302 | 10028614 |
| Method of Manufacturing a Laterally Diffused Metal Oxide Semiconductor Device | United States of America | Granted | 2011-04-19 | 2009-09-08 | 7927940 | 12555082 |
| Method of Manufacturing a Laterally Diffused Metal Oxide Semiconductor Device | United States of America | Granted | 2011-04-19 | 2001-01-04 | 7927939 | 09755826 |
| Semiconductor Polishing Pad Alignment Device For A Polishing Apparatus And Method Of Use | United States of America | Granted | 2003-02-04 | 2000-11-21 | 6514123 | 09718935 |
| Method Of Fabricating A Dielectric Layer | United States of America | Granted | 2002-12-17 | 2000-09-11 | 6495474 | 09659668 |
| Calibration Method For Quantitative Elemental Analysis | United States of America | Granted | 2003-02-11 | 2000-05-09 | 6519543 | 09567359 |
| Method Of Testing An Unknown Sample With An Analytical Tool | United States of America | Granted | 2003-02-11 | 2000-05-09 | 6519542 | 09567373 |
| Cleaning Brush Conditioning Apparatus | United States of America | Granted | 2003-06-17 | 2000-01-25 | 6579797 | 09490912 |
| Composite Polishing Pads For Chemical\{miMechanical Polishing | United States of America | Granted | 2003-04-08 | 2001-02-16 | 6544107 | 09785756 |
| Process For Fabricating Organic Semiconductor Device Involving Selective Patterning | United States of America | Granted | 2002-06-11 | 2000-06-28 | 6403397 | 09605507 |
| Apparatus And Method For Improved Cleaning Of Post-CMP Semiconductor Wafers | United States of America | Granted | 2002-07-23 | 2000-03-22 | 6423149 | 09532688 |
| Apparatus And Method For Reclamation Of Used Polishing Slurry | United States of America | Granted | 2003-05-06 | 2000-09-19 | 6558238 | 09665279 |
| System And Method For The Abatement Of Toxic Constituents Of Effluent Gases | United States of America | Lapsed | 2004-10-05 | 2002-01-23 | 6800255 | 10055583 |
| | (C. C | 0.000 | O. G. T. Date | יו פרט פרט פרט פרט פרט פרט פרט פרט פרט פרט | | |

| High-Resolution Method For Patterning A Substrate With Micro-Printing | United States of America | Granted | 2004-05-18 | 1999-05-05 | 6736985 | 09305722 |
|---|--------------------------|---------|------------|------------|-----------|---------------|
| Selective Etching Of Thin Films | United States of America | Granted | 2001-10-23 | 2000-02-04 | 6306313 | 09497982 |
| Energy-Sensitive Resist Material And A Process For Device Fabrication Using An Energy-Sensitive Resist Material | United States of America | Granted | 2000-04-11 | 1999-03-12 | 6048664 | 09266912 |
| Method Of Forming A Capacitor Having A Tungsten Bottom Electrode In A Semiconductor Wafer | United States of America | Granted | 2001-10-16 | 2000-01-06 | 6303426 | 09478725 |
| Mechanical Planarization | United States of America | Granted | 2002-04-09 | 1999-11-22 | 6368955 | 09444817 |
| Stacked Via Kelvin Resistance Test Structure For Measuring Contact Anomalies In Multi-Level Metal Integrated Circuit Technologies Method Of Polishing Semiconductor Structures Using Chemical | United States of America | Granted | 2002-03-26 | 1999-09-01 | 6362638 | 09388203 |
| Very Low Magnetic Field Integrated Circuit | United States of America | Granted | 2002-07-02 | 1999-07-16 | 6414383 | 09354657 |
| Damascene Structure Having A Metal-Oxide-Metal Capacitor Associated Therewith | United States of America | Granted | 2004-01-20 | 2000-05-18 | 6680542 | 09575214 |
| Electrochemical Mechanical Planarization Apparatus And Method | United States of America | Granted | 2002-04-09 | 2000-01-26 | 6368190 | 09491836 |
| Diffusion Preventing Barrier Layer In Integrated Circuit Inter-Metal Layer Dielectrics | United States of America | Granted | 2004-04-27 | 1999-08-19 | 6727588 | 09377386 |
| Diffusion Preventing Barrier Layer In Integrated Circuit Inter-Metal Layer Dielectrics | United Kingdom | Lapsed | 2002-11-20 | 2000-08-08 | 2359661 | 00194837 |
| Diffusion Preventing Barrier Layer In Integrated Circuit Inter-Metal Layer Dielectrics | Korea, Republic of (KR) | Granted | 2007-09-04 | 2000-08-19 | 757214 | 1020000048028 |
| Diffusion Preventing Barrier Layer In Integrated Circuit Inter-Metal Layer Dielectrics | Taiwan | Granted | 2001-09-01 | 2000-06-26 | NI-139603 | 89112520 |
| Reference Thickness Endpoint Techniques For Polishing Operations | United States of America | Granted | 2001-07-03 | 1999-10-25 | 6254454 | 09426017 |
| Method For Chemical\(sIMechanical Planarization Of A Semiconductor Wafer Having Dissimilar Metal Pattern Densities | United States of America | Granted | 2003-07-22 | 1999-10-08 | 6596639 | 09415529 |
| Charge Technique | United States of America | Granted | 2002-05-21 | 2000-05-01 | 6391668 | 09562346 |
| Semiconductor\(slOxide Interface By A Contactless | | | | | | |
| Method Of Determining A Trap Density Of A | | | | | | |
| Method Of Forming Bipolar Transistors Comprising A Native Oxide Layer Formed On A Substrate By Rinsing The Substrate In Ozinated Water | United States of America | Granted | 2002-09-17 | 2000-06-09 | 6451660 | 09591037 |
| Zone Plates For X-Rays | United States of America | Granted | 2001-07-10 | 1999-07-16 | 6259764 | 09356396 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

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|---------------|-----------|--|------------|------------------|--------------------------|--|
| 09465880 | 6746577 | 1999-12-16 | ∞ | ğ. | United States of America | Method And Apparatus For Thickness Control And Reproducibility Of Dielectric Film Deposition |
| 09390181 | 6387817 | 1999-09-07 | 2002-05-14 | Granted | United States of America | Plasma Confinement Shield |
| 09273299 | 6066884 | 1999-03-19 | 2000-05-23 | Granted | United States of America | Schottky Diode Guard Ring Structures |
| 09363781 | 6175137 | 1999-07-29 | 2001-01-16 | Granted | United States of America | Monolithic Resistor Having Dynamically Controllable Impedance And Method Of Manufacturing The Same |
| | | | | | | Test Structures For Testing Planarization Systems And Methods For Using |
| 09480387 | 6309900 | 2000-01-11 | 2001-10-30 | Granted | United States of America | Same |
| 1020000046955 | 718823 | 2000-08-14 | 2007-05-10 | Granted | Korea, Republic of (KR) | A Silicon-Germanium Transistor And Associated Methods |
| 00194811 | 2356739 | 2000-08-08 | 2002-04-17 | Lapsed | United Kingdom | A Silicon-Germanium Transistor And Associated Methods |
| 89116118 | NI-151814 | 2000-08-10 | 2002-03-11 | | Taiwan | A Silicon-Germanium Transistor And Associated Methods |
| 09375150 | 6235560 | 1999-08-16 | 2001-05-22 | Granted | United States of America | A Silicon-Germanium Transistor And Associated Methods |
| 09370912 | 6287970 | 1999-08-06 | 2001-09-11 | Granted | United States of America | Method Of Making A Semiconductor With Copper Passivating Film |
| 09332216 | 6281128 | 1999-06-14 | 2001-08-28 | Granted | United States of America | Wafer Carrier Modification For Reduced Extraction Force |
| 09263445 | 6307252 | 1999-03-05 | 2001-10-23 | Granted | United States of America | On-Chip Shielding Of Signals |
| 09286430 | 6217427 | 1999-04-06 | 2001-04-17 | Granted | United States of America | Mobius Strip Belt For Linear CMP Tools |
| 09441676 | 6331460 | 1999-11-17 | 2001-12-18 | Granted | United States of America | A Method Of Fabricating A MOM Capacitor Having A Metal Silicide Barrier |
| 09441561 | 6335557 | 1999-11-17 | 2002-01-01 | Granted | United States of America | Metal Silicide As A Barrier For MOM Capacitors In CMOS Technologies |
| 09281642 | 6317643 | 1999-03-31 | 2001-11-13 | Granted | United States of America | Manufacturing And Engineering Data Base |
| 09236763 | 6278105 | 1999-01-25 | 2001-08-21 | Granted | United States of America | Transistor Utilizing Photonic Band\{miGap Material And Integrated Circuit Devices Comprising Same |
| 09197351 | 6246060 | 1998-11-20 | 2001-06-12 | Granted | United States of America | Apparatus For Holding And Aligning A Scanning Electron Microscope Sample |
| 09136095 | 6080671 | 1998-08-18 | 2000-06-27 | Granted | United States of America | Process Of Chemical-Mechanical Polishing And Manufacturing An Integrated Circuit |
| 09099715 | 6121124 | 1998-06-18 | 2000-09-19 | Granted | United States of America | Process For Fabricating Integrated Circuits With Dual Gate Devices Therein |
| 09113583 | 6146975 | 1998-07-10 | 2000-11-14 | Granted | United States of America | Shallow Trench Isolation |
| 08980943 | 5951382 | 1997-12-01 | 1999-09-14 | Granted | United States of America | Chemical Mechanical Polishing Carrier Fixture and System |
| 09039213 | 6043496 | 1998-03-14 | 2000-03-28 | Granted | United States of America | Method Of Linewidth Monitoring For Nanolithography |
| 09062606 | 5897362 | 1998-04-17 | 1999-04-27 | Granted | United States of America | Bonding Silicon Wafers |
| 08878579 | 6007685 | 1997-06-19 | 1999-12-28 | Expired | United States of America | Deposition Of Highly Doped Silicon Dioxide Films |
| | | | | | | Device And Method Of Decreasing Circular Defects And Charge Buildup In |
| 09089792 | 6090534 | 1998-06-03 | 2000-07-18 | Granted | United States of America | Integrated Circuit Fabrication |

| Semi-Insulated Indium Phosphide Based Compositions | United States of America | Granted | 2001-04-03 | 1994-02-22 | 6211539 | 08199910 |
|--|--------------------------|---------|------------|------------|---------|----------|
| Lithographic Masks | United States of America | Expired | 1998-06-09 | 1996-03-27 | 5764390 | 08622795 |
| Holographic Method For Generating Three-Dimensional Conformal Photo- | | | | | | |
| Lithographic Masks | United States of America | Expired | 1998-01-06 | 1996-03-27 | 5705298 | 08622797 |
| Holographic Method For Generating Three-Dimensional Conformal Photo- | | | | | | |
| Inspection Apparatus And Method | United States of America | Expired | 1996-08-27 | 1994-10-03 | 5550583 | 08316745 |
| Method Of Forming Vias | United States of America | Expired | 1997-11-04 | 1995-12-18 | 5683758 | 08573923 |
| Integrated Circuit Fabrication | United States of America | Expired | 1996-07-23 | 1994-12-22 | 5538921 | 08362616 |
| Substrates | United States of America | Expired | 1996-07-09 | 1995-01-10 | 5534465 | 08370902 |
| Method For Making Multichip Circuits Using Active Semiconductor | | | | | | |
| Apparatus And Method For Measuring The Orientation Of A Single Crysta Surface | United States of America | Expired | 1998-06-16 | 1997-02-10 | 5768335 | 08798580 |
| Photosensing Device With Improved Spectral Response And Low Thermal Leakage | United States of America | Expired | 1999-08-24 | 1997-04-30 | 5942775 | 08846769 |
| High Resolution Remote Position Detection Using Segmented Gratings | United States of America | Expired | 1997-08-05 | 1995-08-17 | 5654540 | 08516060 |
| In-situ Doped Silicon Layers | United States of America | Expired | 1999-10-12 | 1996-08-30 | 5966627 | 08705936 |
| Integrated Circuit Processing Utilizing Microwave Radiation | United States of America | Expired | 2000-06-20 | 1995-12-22 | 6078035 | 08577077 |
| Method Of Making A Dielectric For An Integrated Circuit | United States of America | Expired | 1999-09-28 | 1996-12-31 | 5960302 | 08775790 |
| Method Of Polishing | United States of America | Expired | 1998-04-07 | 1996-12-17 | 5735963 | 08767758 |
| Method Of Etching Silicon Materials | United States of America | Expired | 1999-07-27 | 1997-08-01 | 5930650 | 08904527 |
| Shadow Mask Deposition | United States of America | Expired | 2001-08-14 | 1997-02-24 | 6274198 | 08805404 |
| Systems And Method For Determining Semiconductor Wafer Temperature And Calibrating A Vapor Deposition Device | United States of America | Expired | 1999-05-11 | 1997-04-15 | 5902504 | 08834261 |
| Improved P\{miChannel MOS Transistor | United States of America | Expired | 1999-04-13 | 1996-12-05 | 5894154 | 08761052 |
| Tool | United States of America | Granted | 1999-09-14 | 1997-11-14 | 5951372 | 08970298 |
| Method Of Roughing A Metallic Surface Of A Semiconductor Deposition | | | | | | |
| And Method For Making Same | United States of America | Expired | 1999-01-19 | 1997-02-28 | 5861651 | 08807209 |
| Field Effect Devices And Capacitors With Improved Thin Film Dielectrics | | | | | | |
| Process For Electroplating Metals | United States of America | Granted | 2001-07-10 | 1997-12-10 | 6258241 | 08988420 |
| Process For Making Bipolar Having Graded Or Modulated Collector | United States of America | Expired | 1999-12-14 | 1997-06-09 | 6001701 | 08871385 |
| Low Noise, High Power Pseudomorphic HEMT | United States of America | Expired | 1998-09-22 | 1997-07-03 | 5811844 | 08887587 |
| | Coditory | Status | O'CO'CO'CO | | | |

| Reliable metallization with barrier for semiconductors | United States of America | Expired | 1996-06-11 | 1995-06-05 | 5525837 | 08463064 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Method of forming a layer of material on a wafer | United States of America | Expired | 1997-06-03 | 1995-08-28 | 5635244 | 08520058 |
| Wafer Clamp For Chemical Vapor Deposition | United States of America | Abandoned | | 1997-01-23 | | 08788125 |
| Catalytic acceleration and electrical bias control of CMP processing | United States of America | Expired | 1999-09-07 | 1996-05-23 | 5948697 | 08652905 |
| Catalytic acceleration and electrical bias control of CMP processing | United States of America | Expired | 2000-02-29 | 1999-04-27 | 6030425 | 09300823 |
| Hybrid surface/buried-channel MOSFET | United States of America | Expired | 2001-06-12 | 1996-09-25 | 6246093 | 08719773 |
| Hybrid Surface/Buried-Channel MOSFET | United States of America | Abandoned | | 1997-10-31 | | 08962420 |
| MOSFET device with improved LDD region and method of making same | United States of America | Expired | 1998-07-14 | 1997-01-30 | 5780350 | 08791283 |
| Mosfet Device With Improved LDD Region And Method Of Making Same | United States of America | Abandoned | | 1998-05-12 | | 09076249 |
| Local interconnection process for preventing dopant cross diffusion in shared gate electrodes | United States of America | Granted | 2000-03-07 | 1998-02-06 | 6034401 | 09020029 |
| Local interconnection process for preventing dopant cross diffusion in shared gate electrodes | United States of America | Granted | 2002-12-17 | 2000-01-04 | 6495408 | 09477170 |
| Integrated circuit test reticle and alignment mark optimization method | United States of America | Expired | 1997-05-06 | 1994-10-31 | 5627624 | 08302598 |
| Method of using a test reticle to optimize alignment of integrated circuit process layers | United States of America | Expired | 1999-04-27 | 1997-05-05 | 5898478 | 08851607 |
| Detection of CMP Endpoint With Multiple Wavelength Lasers | United States of America | Expired | | 2001-03-06 | | 60273959 |
| Method for CMP endpoint detection | United States of America | Granted | 2002-04-16 | 2001-09-05 | 6372524 | 09946895 |
| Process for removal of photoresist mask used for making vias in low k carbon-doped silicon oxide dielectric material, and for removal of etch residues from formation of vias and removal of photoresist mask | United States of America | Granted | 2004-01-06 | 2001-07-02 | 6673721 | 09898194 |
| Process for removal of photoresist mask used for making vias in low K carbon-doped silicon oxide dielectric material, and for removal of etch residues from formation of vias and removal of photoresist mask | United States of America | Granted | 2006-07-04 | 2003-07-14 | 7071113 | 10619978 |
| Integrated circuit with tungsten plug containing amorphization layer | United States of America | Expired | 2000-01-18 | 1998-04-27 | 6016009 | 09067545 |
| Multistep tungsten CVD process with amorphization step | United States of America | Expired | 1998-09-08 | 1997-02-07 | 5804249 | 08796945 |
| Semiconductor wafer arrangement of a semiconductor wafer | United States of America | Granted | 2004-03-16 | 2002-12-16 | 6707114 | 10321250 |
| Semiconductor wafer arrangement and method of processing a semiconductor wafer | United States of America | Granted | 2003-02-18 | 2001-08-30 | 6521520 | 09943403 |
| On-chip misalignment indication | United States of America | Expired | 2001-04-24 | 1998-09-09 | 6221681 | 09150076 |
| On-chip misalignment indication | United States of America | Expired | 1999-04-27 | 1997-10-03 | 5898228 | 08943371 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Process For Device Fabrication | United States of America | Expired | 81-90-7007 | 199/-0/-29 | 6406952 | 08902044 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| Process For Fabricating Semiconductor Devices In Which The Distribution Of Dopants Is Controlled | | | 2002-12-31 | 2000-08-29 | 6500740 | 09650038 |
| Damascene replacement metal gate process with controlled gate profile and length using Si1-xGex as sacrificial material | United States of America | Abandoned | | 2008-01-29 | | 12021728 |
| Damascene replacement metal gate process with controlled gate profile and length using Si1-xGex as sacrificial material | United States of America | Granted | 2008-04-29 | 2004-07-13 | 7365015 | 10889901 |
| Implementation of Si-Ge HBT with CMOS process | United States of America | Granted | 2004-07-27 | 2002-07-09 | 6767842 | 10191670 |
| Implementation of Si-Ge HBT Module with CMOS Process | United States of America | Abandoned | | 2004-05-04 | | 10838384 |
| Apparatus and method to improve the resolution of photolithography systems by improving the temperature stability of the reticle | United States of America | Lapsed | 2005-03-15 | 2002-10-07 | 6866970 | 10265856 |
| Apparatus and method to improve the resolution of photolithography systems by improving the temperature stability of the reticle | United States of America | Lapsed | 2008-06-03 | 2004-09-16 | 7381502 | 10942444 |
| Image-sensing display panels with LCD display panel and photosensitive element array | United States of America | Expired | 1994-08-23 | 1993-04-21 | 5340978 | 08051028 |
| Sensing device for capturing a light image | United States of America | Expired | 1997-07-15 | 1995-12-26 | 5648655 | 08578746 |
| Color electronic camera including photosensor array having binary diffractive lens elements | United States of America | Expired | 1996-05-21 | 1994-08-08 | 5519205 | 08287204 |
| Electronic camera with binary lens element array | United States of America | Expired | 1998-06-02 | 1994-08-08 | 5760834 | 08287128 |
| Camera Based Devices | United States of America | Abandoned | | 1993-02-11 | | 08017202 |
| Light sensing device having an array of photosensitive elements coincident with an array of lens formed on an optically transmissive material | United States of America | Expired | 1999-11-02 | 1997-05-27 | 5977535 | 08863372 |
| Image-sensing display panels with LCD display panel and photosensor array | United States of America | Expired | 1995-07-11 | 1994-08-22 | 5432333 | 08294076 |
| Camera | United States of America | Abandoned | | 1992-09-30 | | 07954958 |
| Low dielectric constant fluorine and carbon-containing silicon oxide dielectric material characterized by improved resistance to oxidation | United States of America | Lapsed | 2006-03-21 | 2003-08-29 | 7015168 | 10652007 |
| Process for forming a low dielectric constant fluorine and carbon-containing silicon oxide dielectric material characterized by improved resistance to oxidation | United States of America | | 2003-11-18 | 2001-02-23 | 6649219 | 09792691 |
| Method of making self-aligned remote polysilicon contacts | United States of America | | 1997-10-07 | 1995-06-07 | 5674774 | 08474794 |
| Self-Aligned Remote Polysilicon Contacts | United States of America | Abandoned | | 1997-10-02 | | 08942511 |
| Method for fabricating reliable metallization with Ta-Si-N barrier for semiconductors | United States of America | Expired | 1997-03-25 | 1995-01-26 | 5614437 | 08378750 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
| | | | | | | |

| Device Comprising Micromagnetic Components For Power Applications And Process For Forming Device | United States of America | Granted | 2002-12-17 | 2000-04-19 | 6495019 | 09552627 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Micromagnetic Device Having Alloy Of Combalt, Phosphorus and Iron | United States of America | Granted | 2003-09-23 | 2001-12-20 | 6624498 | 10028594 |
| Local interconnect for integrated circuit | United States of America | Lapsed | 2006-07-25 | 2005-02-15 | 7081379 | 11058498 |
| Local interconnect for integrated circuit | United States of America | Lapsed | 2005-03-29 | 2003-03-06 | 6872612 | 10383149 |
| A Projection Lithography Apparatus | United States of America | Expired | 1997-12-23 | 1996-06-25 | 5701014 | 08673705 |
| A Process For Device Fabrication Using Projection Lithography And An Apparatus Therefor | United States of America | Expired | 1996-10-01 | 1995-01-27 | 5561008 | 08379052 |
| | United States of America | Expired | 1997-06-10 | 1994-10-31 | 5637950 | 08331458 |
| Field Emission Devices Employing Enhanced Diamond Field Emitters | United States of America | Expired | 1998-04-28 | 1996-11-19 | 5744195 | 08752234 |
| Field Emission Devices Employing Enhanced Diamond Field Emitters | United States of America | Expired | 1998-09-22 | 1996-11-19 | 5811916 | 08752235 |
| THIN FILM CAPACITORS AND PROCESS FOR MAKING THEM | United States of America | Expired | 2000-06-13 | 1997-08-25 | 6075691 | 08918174 |
| Thin Film Tantalum Oxide Capacitors And Resulting Product | United States of America | Expired | 1999-08-10 | 1997-03-06 | 5936831 | 08814051 |
| Method for Removing Etching Residues and Contaminants | United States of America | Granted | 2000-04-04 | 1998-10-01 | 6046115 | 09164283 |
| Method For Removing Etching Residues And Contaminants | United States of America | Granted | 1998-12-15 | 1997-11-26 | 5849639 | 08979297 |
| Process For Semiconductor Device Fabrication In Which A Insulating Layer Is Formed On A Semiconductor Substrate | United States of America | Abandoned | | 2004-06-17 | | 10870834 |
| Layer Is Formed On A Semiconductor Substrate | United States of America | Granted | 2004-08-03 | 2002-10-03 | 6770536 | 10263638 |
| Wetnod For Forming Wetal Silicide Regions In An Integrated Circuit | United States of America | Granted | 2007-07-31 | 2002-09-17 | 7250356 | 10245447 |
| Integrated Circuit With Metal Silicide Regions | United States of America | Lapsed | 2010-09-21 | 2007-06-22 | 7800226 | 11821396 |
| Electrostatic Discharge Protection In Double Diffused MOS Transistors | United States of America | Granted | 2003-06-10 | 2001-06-29 | 6576506 | 09896669 |
| Electrostatic Discharge Protection In Double Diffused MOS Transistors | United States of America | Lapsed | 2004-11-23 | 2003-04-08 | 6821831 | 10409423 |
| Method of shallow trench isolation formation and planarization | United States of America | Lapsed | 2005-09-27 | 2003-06-09 | 6949446 | 10457942 |
| Method of shallow trench isolation formation and planarization | United States of America | Granted | 2003-09-09 | 2001-06-19 | 6617251 | 09885497 |
| A Vertical Replacement-Gate Junction Field-Effect Transistor | United States of America | Lapsed | 2006-04-25 | 2003-11-26 | 7033877 | 10723547 |
| Vertical Replacement-Gate Junction Field-Effect Transistor | United States of America | Granted | 2004-02-10 | 2001-09-10 | 6690040 | 09950384 |
| A Vertical Replacement-Gate Junction Field-Effect Transistor | United States of America | Abandoned | | 2006-03-27 | | 11390015 |
| The Use Of Selective Oxidation To Improve LDMOS Power Transistors | United States of America | Granted | 2003-01-14 | 2000-08-17 | 6506641 | 09641086 |
| LDMOS Device Having A Tapered Oxide | United States of America | Granted | 2004-07-13 | 2002-11-20 | 6762457 | 10300254 |
| Method For Making An Integrated Circuit Device With Dielectrically Isolated Tubs and Related Circuit | United States of America | Granted | 2002-12-31 | 2000-12-01 | 6500717 | 09728448 |
| Method For Making An Integrated Circuit Device With Dielectrically Isolated Tubs And Related Circuit | United States of America | Lapsed | 2006-01-24 | 2002-10-17 | 6989552 | 10272734 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Apparatus For Verification Of IC Mask Sets | United States of America | Granted | 2003-03-04 | 2000-03-17 | 6530074 | 09528071 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Low temperature coefficient resistor | United States of America | Lapsed | 2005-11-01 | 2003-07-08 | 6960979 | 10615039 |
| Low temperature coefficient resistor | United States of America | Granted | 2003-09-16 | 2001-10-23 | 6621404 | 10002413 |
| Apparatus for washing drums | United States of America | Lapsed | 2004-01-06 | 2003-02-20 | 6672320 | 10370812 |
| Method and apparatus for washing drums | United States of America | Granted | 2003-05-06 | 2000-10-16 | 6557566 | 09690047 |
| Forming a semiconductor on implanted insulator | United States of America | Granted | 2003-09-02 | 2002-01-30 | 6613639 | 10060867 |
| Integration of semiconductor on implanted insulator | United States of America | Granted | 2004-07-27 | 2003-06-24 | 6768130 | 10602510 |
| System To Improve SER Immunity And Punchthrough | United States of America | Abandoned | | 2002-07-09 | | 10191107 |
| System to improve SER immunity and punchthrough | United States of America | Granted | 2002-09-24 | 2000-07-03 | 6455363 | 09609527 |
| Process for wafer edge profile control using gas flow control ring | United States of America | Granted | 2004-06-22 | 2002-07-18 | 6753255 | 10200469 |
| Process and Apparatus for Wafer Edge Profile Control Using Gas Flow Control Ring | United States of America | Abandoned | | 2004-04-09 | | 10821708 |
| Process and Apparatus for Water Edge Profile Control Using Gas Flow Control Ring | United States of America | Expired | | 2002-05-17 | | 60381746 |
| Adaptive off tester screening method based on intrinsic die parametric measurements | United States of America | Lapsed | 2004-10-19 | 2002-07-16 | 6807655 | 10197956 |
| | United States of America | Granted | 2002-05-21 | 1999-10-22 | 6391/95 | 09426056 |
| Low k dielectric composite layer for intergrated circuit structure which provides void-free low k dielectric material between metal lines while | | | | | | |
| Low k dielectric composite layer for integrated circuit structure which provides void-free low k dielectric material between metal lines while mitigating via poisoning | United States of America | Granted | 2004-10-05 | 2002-03-15 | 6800940 | 10099641 |
| Arrangement and method for polishing a surface of a semiconductor wafer | United States of America | Granted | 2002-08-27 | 2000-12-28 | 6439981 | 09750639 |
| Arrangement and method for polishing a surface of a semiconductor wafer | United States of America | Granted | 2003-04-29 | 2002-06-07 | 6555475 | 10164909 |
| In-situ metrology system and method for monitoring metalization and other thin film formation | United States of America | Granted | 2008-08-19 | 2002-12-23 | 7414721 | 10328066 |
| In-Situ Metrology System and Method for Monitoring Metalization and Other Thin Film Formation | United States of America | Abandoned | | 2008-07-25 | | 12220644 |
| Endpoint detection method and apparatus which utilize a chelating agent to detect a polishing endpoint | United States of America | Granted | 2000-09-12 | 1998-12-15 | 6117779 | 09212503 |
| Endpoint detection method and apparatus which utilize a chelating agent to detect a polishing endpoint | United States of America | Granted | 2002-05-07 | 2000-05-31 | 6383332 | 09583434 |
| Local interconnect | United States of America | Granted | 2003-06-10 | 2001-09-28 | 6576544 | 09966464 |
| Local interconnect | United States of America | Lapsed | 2005-08-09 | 2003-03-27 | 6927494 | 10400279 |
| Simplified High Q Inductor Substrate | United States of America | Granted | 2002-06-25 | 2001-03-05 | 6410974 | 09800049 |
| Simplified High Q Inductor Substrate | United States of America | Granted | 2001-05-01 | 1999-08-30 | 6225182 | 09386132 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Capacitor with Stoichiometrically Adjusted Dielectric and Method of Fabricating Same | United States of America | Abandoned | | 2005-05-05 | | 11122375 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Capacitor with stoichiometrically adjusted dielectric and method of fabricating same | United States of America | Lapsed | 2005-10-04 | 2003-03-06 | 6951787 | 10382709 |
| Capacitor with stoichiometrically adjusted dielectric and method of fabricating same | United States of America | Granted | 2003-05-20 | 2000-05-17 | 6566186 | 09573137 |
| Field Emission Devices Employing Diamond Particle Emitters | United States of America | Expired | 1999-11-02 | 1998-01-13 | 5977697 | 09006347 |
| Method Of Making Field Emission Devices Employing Ultra-Fine Diamond Particle Emitters | United States of America | Expired | 1998-01-20 | 1994-12-22 | 5709577 | 08361616 |
| And Methods For Making Same | United States of America | Expired | 1997-04-01 | 1995-01-31 | 5616368 | 08381375 |
| Protruding Spacers For Self-Aligned Contacts Field Emission Positors Employing Activated Disposed Bartisle Emission | United States of America | Granted | 2008-02-19 | 2006-10-04 | 7332775 | 11542864 |
| Protruding Spacers For Self-Aligned Contacts | United States of America | Lapsed | 2006-10-24 | 2002-09-03 | 7126198 | 10234354 |
| Current Drive | United States of America | Expired | 1997-04-29 | 1995-12-14 | 5625200 | 08572196 |
| Current Drive of TFTs in High\(miSpeed SRAMs | United States of America | Expired | 2000-04-25 | 1997-04-28 | 6054722 | 08848141 |
| Electrical Devices Having Adjustable Electrical Characteristics | United States of America | Granted | 2008-11-25 | 2003-12-24 | 7456716 | 10746824 |
| Electrical Devices Having Adjustable Capacitance | United States of America | Granted | 2011-06-14 | 2008-10-17 | 7960812 | 12253403 |
| Reverse\(miBiased Emitter\(miBase Junction | United States of America | Expired | 1999-09-07 | 1998-03-30 | 5949128 | 09050711 |
| Rinolar Transistor With MOS\/miControlled Protection For | | | | | | |
| Bipolar Transistor With MOS-Controlled Protection For Reverse-Biased Emitter-Base Junction | United States of America | Expired | 1998-06-30 | 1995-11-21 | 5773338 | 08562235 |
| Locos Isolation Process Using A Layered Pad Nitride And Dry Field Oxidation Stack And Semiconductor Device Employing The Same | United States of America | Expired | 2002-04-30 | 1998-12-02 | 6380606 | 09205413 |
| COCO'S Isolation Process Using Layered PAD Nitride And Dry Field Oxidation Stack And Semiconductor Device Employing The Same | United States of America | Expired | 2000-07-18 | 1997-06-18 | 6090686 | 08878242 |
| Interdigitated Capacitor And Method Of Manufacturing Thereof | United States of America | Granted | 2004-05-25 | 2001-08-14 | 6740922 | 09929188 |
| Interdigitated Capacitor And Method Of Manufacturing Thereof | United States of America | Granted | 2005-08-09 | 2004-02-11 | 6927125 | 10776752 |
| Capacitor Having The Lower Electrode For Preventing Undesired Defects At The Surface Of The Metal Plug | United States of America | Granted | 2003-02-25 | 2001-09-13 | 6525358 | 09951178 |
| Integrated Circuit Capacitor And Associated Fabrication Methods | United States of America | Granted | 2001-11-27 | 1999-09-29 | 6323044 | 09408299 |
| Article Comprising Vertically Nano-InterConnected Circuit Devices And Method For Making The Same | United States of America | Granted | 2002-01-22 | 1999-10-05 | 6340822 | 09426457 |
| Article Comprising Vertically Nano-InterConnected Circuit Devices And Method For Making The Same | United States of America | Granted | 2002-05-07 | 2000-08-22 | 6383923 | 09643784 |
| Segmented Emitter Low Noise Transistor | United States of America | Expired | 1998-03-03 | 1995-06-07 | 5723897 | 08484675 |
| Method of Fabricating a Segmented Emitter Low Noise Transistor | United States of America | Expired | 1998-10-13 | 1996-07-12 | 5821148 | 08678971 |
| Method Of Verifying IC Mask Sets | United States of America | Lapsed | 2006-09-05 | 2002-12-11 | 7103869 | 10317147 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|----------|----------|------------|------------|-----------|--------------------------|---|
| 09960765 | 6504219 | 2001-09-21 | 2003-01-07 | Granted | United States of America | Indium field implant for punchthrough protection in semiconductor devices |
| 09469579 | 6342429 | 1999-12-22 | 2002-01-29 | Granted | United States of America | Method of fabricating an indium field implant for punchthrough protection in semiconductor devices |
| 09211024 | 6168502 | 1998-12-14 | 2001-01-02 | Expired | United States of America | Subsonic to supersonic and ultrasonic conditioning of a polishing pad in a chemical mechanical polishing apparatus |
| 08696445 | 5868608 | 1996-08-13 | 1999-02-09 | Expired | United States of America | Subsonic to supersonic and ultrasonic conditioning of a polishing pad in a chemical mechanical polishing apparatus |
| 09052851 | 6057571 | 1998-03-31 | 2000-05-02 | Granted | United States of America | High aspect ratio, metal-to-metal, linear capacitor for an integrated circuit |
| 09221023 | 6251740 | 1998-12-23 | 2001-06-26 | Granted | United States of America | Method of forming and electrically connecting a vertical interdigitated metal-insulator-metal capacitor extending between interconnect layers in an integrated circuit |
| 09219655 | 6417535 | 1998-12-23 | 2002-07-09 | Granted | United States of America | Vertical interdigitated metal-insulator-metal capacitor for an integrated circuit |
| 09052793 | 6358837 | 1998-03-31 | 2002-03-19 | Granted | United States of America | Method of electrically connecting and isolating components with vertical elements extending between interconnect layers in an integrated circuit |
| 09525489 | 6441419 | 2000-03-15 | 2002-08-27 | Granted | United States of America | Encapsulated-metal vertical-interdigitated capacitor and damascene method of manufacturing same |
| 09907424 | 6489231 | 2001-07-17 | 2002-12-03 | Granted | United States of America | Method for forming barrier and seed layer |
| 10268735 | | 2002-10-10 | | Abandoned | United States of America | Barrier and Seed Layer System Method of single step damascene process for deposition and global |
| 09027307 | 6004880 | 1998-02-20 | 1999-12-21 | Granted | United States of America | |
| 09365440 | 6090239 | 1999-08-02 | 2000-07-18 | Granted | United States of America | Method of single step damascene process for deposition and global planarization |
| 08604867 | 5688709 | 1996-02-14 | 1997-11-18 | Expired | United States of America | Method for forming composite trench-fin capacitors for DRAMS |
| 08879341 | 6081008 | 1997-06-20 | 2000-06-27 | Expired | United States of America | Composite trench-fin capacitors for DRAM |
| 08552461 | 5670425 | 1995-11-09 | 1997-09-23 | Expired | United States of America | Process for making integrated circuit structure comprising local area interconnects formed over semiconductor substrate by selective deposition on seed layer in patterned trench |
| 08873809 | 5895261 | 1997-06-12 | 1999-04-20 | Expired | United States of America | Process for making integrated circuit structure comprising local area interconnects formed over semiconductor substrate by selective deposition on seed layer in patterned trench |
| 09454257 | 6297558 | 1999-12-02 | 2001-10-02 | Expired | United States of America | Slurry filling a recess formed during semiconductor fabrication |
| 08899111 | 6069085 | 1997-07-23 | 2000-05-30 | Expired | United States of America | Slurry filling a recess formed during semiconductor fabrication |

| Failure analysis and testing of semi-conductor devices using intelligent software on automated test equipment (ATE) | United States of America | Granted | 2008-09-30 | 2007-02-01 | 7430700 | 11670031 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Failure Analysis and Testing of Semi-Conductor Devices Using Intelligent Software on Automated Test Equipment (ATE) | United States of America | Lapsed | 2009-07-21 | 2007-12-27 | 7565592 | 11964920 |
| Apparatus For Igniting Low Pressure Inductively Coupled Plasma | United States of America | Abandoned | | 1997-12-08 | | 08986681 |
| Apparatus and method using optical energy for specifying and quantitatively controlling chemically-reactive components of semiconductor processing plasma etching gas | United States of America | Expired | 1997-12-09 | 1995-06-07 | 5696428 | 08485517 |
| Dual layer barrier film techniques to prevent resist poisoning | United States of America | Granted | 2004-11-02 | 2001-06-28 | 6812134 | 09896363 |
| Dual layer barrier film techniques to prevent resist poisoning | United States of America | Granted | 2008-07-01 | 2006-05-04 | 7393780 | 11418873 |
| Dual layer barrier film techniques to prevent resist poisoning | United States of America | Granted | 2006-07-04 | 2004-07-16 | 7071094 | 10893659 |
| Method of wafer patterning for reducing edge exclusion zone | United States of America | Lapsed | 2006-07-11 | 2004-11-03 | 7074710 | 10980945 |
| Apparatus for wafer patterning to reduce edge exclusion zone | United States of America | Lapsed | 2008-12-02 | 2006-05-12 | 7460211 | 11383171 |
| Oxide formed in semiconductor substrate by implantation of substrate with a noble gas prior to oxidation | United States of America | Expired | 1998-01-13 | 1995-05-04 | 5707888 | 08434674 |
| Oxide formed in semiconductor substrate by implantation of substrate with a noble gas prior to oxidation | United States of America | Expired | 1998-04-14 | 1997-01-27 | 5739580 | 08788403 |
| Microelectronic integrated circuit including triangular semiconductor and gate device | United States of America | Expired | 1997-05-20 | 1995-12-06 | 5631581 | 08567952 |
| Microelectronic Integrated Circuit Including Triangular Semiconductor And Gate Device | United States of America | Abandoned | | 1995-05-10 | | 08438613 |
| Product Resulting From Selective Deposition Of Polysilicon Over Single Crystal Silicon Substrate | United States of America | Abandoned | | 1995-11-30 | | 08566161 |
| Product resulting from selective deposition of polysilicon over single crystal silicon substrate | United States of America | Expired | 1998-10-06 | 1997-03-25 | 5818100 | 08823829 |
| Process for selective deposition of polysilicon over single crystal silicon substrate and resulting product | United States of America | Expired | 1997-07-08 | 1995-01-18 | 5646073 | 08374193 |
| Self-aligned twin well process having a SiO2-polysilicon-SiO2 barrier mask | United States of America | Expired | 1996-12-10 | 1995-06-07 | 5583062 | 08488075 |
| Self-aligned twin well process | United States of America | Expired | 1998-06-23 | 1996-12-18 | 5770492 | 08768845 |
| Self-aligned twin well process | United States of America | Expired | 1998-06-09 | 1996-08-20 | 5763302 | 08704472 |
| Process and structure for reduction of channeling during implantation of source and drain regions in formation of MOS integrated circuit structures | United States of America | Expired | 1997-03-25 | 1995-10-23 | 5614428 | 08546921 |
| Structure For Reduction Of Channeling During Implantation Of Source And Drain Regions In Formation Of Mos Integrated Circuit Structures | United States of America | Abandoned | | 1996-11-19 | | 08752334 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Patentify Pate | Layout configuration for an integrated circuit gate array | United States of America | Expired | 1997-08-19 | 1995-06-07 | 5659189 | 08473543 |
|--|---|--------------------------|-----------|------------|------------|----------|----------|
| Patentivo FriedDate Status Country | Yield Profile Manipulator | United States of America | Granted | 2011-04-19 | 2008-05-08 | 7930655 | 12117379 |
| PatentiNo | Yield profile manipulator | United States of America | Granted | 2008-07-01 | 2004-03-16 | 7395522 | 10801310 |
| PatentiNo | Planarization with Reduced Dishing | United States of America | Abandoned | | 2007-04-02 | | 11695169 |
| PatentiNo | Planarization with reduced dishing | United States of America | Lapsed | 2006-04-18 | 2003-04-23 | 7029591 | 10421068 |
| Patentillo | Planarization with reduced dishing | United States of America | Granted | 2007-05-22 | 2006-01-23 | 7220362 | 11337460 |
| PatentiNo FiledDate GrantDate Status Country | Metal planarization system | United States of America | Lapsed | 2005-10-04 | 2003-03-27 | 6951808 | 10400278 |
| PatentiNo FiledDate GrantDate Status Country | Metal planarization system | United States of America | Lapsed | 2003-07-01 | 2001-03-13 | 6586326 | 09804783 |
| PatentNo | Gate Dielectrics | United States of America | Granted | 2012-08-14 | 2011-12-05 | 8241986 | 13311299 |
| PatentiNo FriedDate GrantDate Status Country 95 7203877 2005-01-04 2007-04-10 Granted United States of America 84 5897381 1997-10-21 1999-04-17 Expired United States of America 90 8404960 1997-10-21 1998-05-26 Expired United States of America 90 8404960 2004-08-31 2013-03-26 Granted United States of America 92 8653357 2013-02-25 2014-02-18 Lapsed United States of America 138 7129101 2004-08-18 2006-10-31 Lapsed United States of America 198 7420229 2006-09-25 2008-09-02 Granted United States of America 198 7420229 2006-09-25 2008-09-02 Granted United States of America 198 5781151 2002-11-27 2004-08-24 Granted United States of America 198 5717238 1995-07-09 1998-02-10 Expired United States of America 1 | Semiconductor Device And Process For Reducing Damaging Breakdown In | | | | | | |
| PatientiNo FiledDate GrantDate Status Country | Gate Dielectrics | United States of America | Granted | 2012-01-03 | 2006-06-20 | 8089130 | 11425295 |
| PatentiNo FiledDate GrantDate Status Country 95 7203877 2005-01-04 2007-04-10 Granted United States of America 84 5897381 1997-10-21 1999-04-17 Expired United States of America 91 5893952 1997-10-21 1999-04-13 Expired United States of America 190 8404960 2004-08-31 2013-03-26 Expired United States of America 192 8653357 2013-02-25 2014-02-18 Lapsed United States of America 192 7420229 2006-09-25 2008-09-02 Granted United States of America 198 7420229 2006-09-25 2008-09-02 Granted United States of America 198 7517238 1995-08-31 1996-12-17 Expired United States of America 198 5717238 1996-07-09 1998-02-10 Expired United States of America 193 563855 1996-07-25 1997-05-20 Expired United States of America <td< td=""><td>Semiconductor Device And Process For Reducing Damaging Breakdown In</td><td></td><td></td><td></td><td></td><td></td><td></td></td<> | Semiconductor Device And Process For Reducing Damaging Breakdown In | | | | | | |
| PatentiNo FiledDate GrantDate Status Country 95 7203877 2005-01-04 2007-04-10 Granted United States of America 99 5897381 1997-10-21 1999-04-27 Expired United States of America 91 5893952 1997-10-21 1999-04-13 Expired United States of America 190 8404960 2004-08-31 1998-05-26 Expired United States of America 222 8653357 2013-02-25 2014-02-18 Lapsed United States of America 38 7129101 2004-08-18 2006-10-31 Lapsed United States of America 198 7420229 2004-08-18 2006-10-31 Lapsed United States of America 198 6781151 2002-11-27 2004-08-24 Granted United States of America 195 5585286 1995-08-31 1996-12-17 Expired United States of America 197 566 5543643 1996-07-09 1998-02-10 Expired United States of America | Process monitor for CMOS integrated circuits | United States of America | Expired | 1997-05-20 | 1995-07-25 | 5631596 | 08506821 |
| PatentNo | Process monitor for CMOS integrated circuits | United States of America | Expired | 1996-01-23 | 1994-08-09 | 5486786 | 08287653 |
| PatentNo | Process monitor for CMOS integrated circuits | United States of America | Expired | 1997-11-11 | 1995-12-26 | 5686855 | 08578743 |
| PatentiNo FiledDate GrantDate Status Country 95 7203877 2005-01-04 2007-04-10 Granted United States of America 84 5897381 1997-10-21 1999-04-27 Expired United States of America 91 5893952 1997-10-21 1999-04-13 Expired United States of America 18 5756369 1996-07-11 1998-05-26 Expired United States of America 90 8404960 2004-08-31 2013-02-25 Expired United States of America 122 8653357 2013-02-25 2014-02-18 Lapsed United States of America 08 7420229 2006-09-25 2008-09-02 Granted United States of America 198 6781151 2002-11-27 2004-08-24 Granted United States of America 195 5585286 1995-08-31 1996-12-17 Expired United States of America 198 5717238 1996-07-09 1998-02-10 Expired United States of America 1 | | United States of America | Expired | 1997-05-20 | 1996-03-06 | 5631176 | 08612337 |
| Patentilyo FiledDate GrantDate Status Country 7203877 2005-01-04 2007-04-10 Granted United States of America 1997-10-21 1999-04-27 Expired United States of America 1997-10-21 1999-04-13 Expired United States of America 1990 8404960 2004-08-31 2013-03-26 Granted United States of America 1900 8404960 2004-08-31 2013-03-26 Granted United States of America 1922 8653357 2013-02-25 2014-02-18 Lapsed United States of America 1938 7129101 2004-08-18 2006-10-31 Lapsed United States of America 194 Granted United States of America 195 5585286 1995-08-31 1996-12-17 Expired United States of America 1995-08-31 1996-12-17 Expired United States of America 1995-08-31 1996-07-09 1998-02-10 Expired United States of America 1995-08-31 1996-07-09 1998-02-10 Expired United States of America 1995-08-08-08-08-08-08-08-08-08-08-08-08-08- | Combined JFET and MOS transistor device, circuit | United States of America | Expired | 1996-08-06 | 1995-07-13 | 5543643 | 08502566 |
| PatentiNo | device | United States of America | Expired | 1998-02-10 | 1996-07-09 | 5717238 | 08677078 |
| PatentNo | and/or diffusion of a boron dopant forming P-LDD region of a PMOS | | | | | | |
| PatentiNo | Substrate with controlled amount of noble gas ions to reduce channeling | | | | | | |
| PatentNo FriedDate GrantDate Status Country 95 7203877 2005-01-04 2007-04-10 Granted United States of America 84 5897381 1997-10-21 1999-04-27 Expired United States of America 91 5893952 1997-10-21 1999-04-13 Expired United States of America 18 5756369 1996-07-11 1998-05-26 Expired United States of America 90 8404960 2004-08-31 2013-03-26 Granted United States of America 122 8653357 2013-02-25 2014-02-18 Lapsed United States of America 08 7129101 2004-08-18 2006-10-31 Lapsed United States of America 08 7420229 2006-09-25 2008-09-02 Granted United States of America 18 6781151 2002-11-27 2004-08-24 Granted United States of America | PMOS device | United States of America | Expired | 1996-12-17 | 1995-08-31 | 5585286 | 08521795 |
| PatentNo FiledDate GrantDate Status Country 95 7203877 2005-01-04 2007-04-10 Granted United States of America 184 5897381 1997-10-21 1999-04-27 Expired United States of America 191 5893952 1997-10-21 1999-04-13 Expired United States of America 18 5756369 1996-07-11 1998-05-26 Expired United States of America 90 8404960 2004-08-31 2013-03-26 Granted United States of America 122 8653357 2013-02-25 2014-02-18 Lapsed United States of America 138 7129101 2004-08-18 2006-10-31 Lapsed United States of America 108 7420229 2006-09-25 2008-09-02 Granted United States of America 118 6781151 2002-11-27 2004-08-24 Granted United States of America | subsequently implanted into the substrate to form P-LDD region of a | | | | | | |
| PatentNo FiledDate GrantDate Status Country Interest 95 7203877 2005-01-04 2007-04-10 Granted United States of America software 84 5897381 1997-10-21 1999-04-27 Expired United States of America Method 91 5893952 1997-10-21 1999-04-13 Expired United States of America Apparati 18 5756369 1996-07-11 1998-05-26 Expired United States of America Rapid th 192 8404960 2004-08-31 2013-03-26 Granted United States of America Method 192 8653357 2013-02-25 2014-02-18 Lapsed United States of America Method 138 7129101 2004-08-18 2006-10-31 Lapsed United States of America burnin ca 18 6781151 2006-09-25 2008-09-02 Granted United States of America burnin ca 18 6781151 2006-10-31 Lapsed United States of America burnin ca | noble gas ions to reduce channeling and/or diffusion of a boron dopant | | | | | | |
| PatentNo | Implantation of a semiconductor substrate with controlled amount of | | | | | | |
| PatentiNo FriedDate GrantDate Status Country little 95 7203877 2005-01-04 2007-04-10 Granted United States of America software 84 5897381 1997-10-21 1999-04-27 Expired United States of America Method 91 5893952 1997-10-21 1999-04-13 Expired United States of America Apparat 18 5756369 1996-07-11 1998-05-26 Expired United States of America Rapid th 190 8404960 2004-08-31 2013-03-26 Granted United States of America Method 122 8653357 2013-02-25 2014-02-18 Lapsed United States of America Method 198 7129101 2004-08-18 2006-10-31 Lapsed United States of America Failure a 198 7420229 2006-09-25 2008-09-02 Granted United States of America burnin ca | Failure analysis vehicle | United States of America | Granted | 2004-08-24 | 2002-11-27 | 6781151 | 10307018 |
| PatentNo | burnin capability for reliability testing | United States of America | Granted | 2008-09-02 | 2006-09-25 | 7420229 | 11527108 |
| PatentNo | Failure analysis vehicle for yield enhancement with self test at speed | | | | | | |
| PatentNo | burnin capability for reliability testing | United States of America | Lapsed | 2006-10-31 | 2004-08-18 | 7129101 | 10921538 |
| PatentNo | Failure analysis vehicle for yield enhancement with self test at speed | | | | | | |
| PatentNo | | United States of America | Lapsed | 2014-02-18 | 2013-02-25 | 8653357 | |
| PatentNo | | United States of America | Granted | 2013-03-26 | 2004-08-31 | 8404960 | 10930590 |
| PatentNo FriedDate GrantDate Status Country little Failure a 2005-01-04 2007-04-10 Granted United States of America Software Status Sep39381 1997-10-21 1999-04-27 Expired United States of America Method United States of America Method United States of America Apparation (Country Country (Country Country (Country Country (Country Country (Country Country (Country Country (Country (Country Country (Country (Countr | feedback | United States of America | Expired | 1998-05-26 | 1996-07-11 | 5756369 | 08678718 |
| PatentNo FriedDate GrantDate Status Country little Failure a 2005-01-04 2007-04-10 Granted United States of America Software Septrated Septrates of America Indicates of America Septrates of America Indicates Indic | Rapid thermal processing using a narrowband infrared source and | | | | | | |
| PatentNo FriedDate GrantDate Status Country lifte Failure a PatentNo FriedDate GrantDate Status Country lifte Failure a PatentNo FriedDate GrantDate Status Country lifte Failure a PatentNo FriedDate GrantDate Status Country lifte | Apparatus for rapid thermal processing of a wafer | United States of America | Expired | 1999-04-13 | 1997-10-21 | 5893952 | 08954791 |
| PatentNo FriedDate GrantDate Status Country little Failure a 7203877 2005-01-04 2007-04-10 Granted United States of America software | | United States of America | Expired | 1999-04-27 | 1997-10-21 | 5897381 | 08955384 |
| PatentNo FiledDate GrantDate Status Country | Failure analysis and testing of semi-conductor devices using intelligent software on automated test equipment (ATE) | United States of America | Granted | 2007-04-10 | 2005-01-04 | 7203877 | 11028695 |
| | Title | Country | Status | GrantDate | HiledDate | PatentNo | AppNo |

| Low voltage breakdown element for ESD trigger device | United States of America | Granted | 2004-03-23 | 2002-01-22 | 6710990 | 10055082 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Low voltage breakdown element for ESD trigger device | United States of America | Granted | 2005-02-15 | 2003-11-12 | 6855586 | 10706120 |
| Method of forming a low k polymer E-beam printable mechanical support | United States of America | Granted | 2008-04-15 | 2005-09-12 | 7358594 | 11225310 |
| Low k polymer E-beam printable mechanical support | United States of America | Lapsed | 2005-12-06 | 2002-12-23 | 6972217 | 10328614 |
| submicron twin-well process | United States of America | Granted | 2005-12-27 | 2003-10-01 | 6979869 | 10676602 |
| I/O and Power ESD Protection Circuits by Enhancing Substrate-Bias In Deep-Submicron CMOS Process | United States of America | Granted | 2012-09-18 | 2011-05-18 | 8269280 | 13110581 |
| I/O and Power ESD Protection Circuits by Enhancing Substrate-Bias In Deep-Submicron CMOS Process | United States of America | Granted | 2011-05-24 | 2009-07-21 | 7948036 | 12506746 |
| I/O and Power ESD Protection Circuits by Enhancing Substrate-Bias In Deep-Submicron CMOS Process | United States of America | Lapsed | 2009-09-01 | 2005-10-25 | 7582938 | 11258253 |
| Method of forming integrated circuit structure having low dielectric constant material and having silicon oxynitride caps over closely spaced apart metal lines | United States of America | Granted | 2002-07-23 | 1999-10-22 | 6423628 | 09425552 |
| Integrated circuit structure having low dielectric constant material and having silicon oxynitride caps over closely spaced apart metal lines | United States of America | Granted | 2004-09-21 | 2002-05-21 | 6794756 | 10153011 |
| Wafer chucking apparatus for spin processor | United States of America | Granted | 2007-04-10 | 2006-04-11 | 7201176 | 11403137 |
| Wafer chucking apparatus and method for spin processor | United States of America | Lapsed | 2006-06-06 | 2003-04-16 | 7056392 | 10417708 |
| Interconnect dielectric tuning | United States of America | Lapsed | 2006-07-25 | 2004-08-10 | 7081406 | 10915719 |
| Interconnect dielectric tuning | United States of America | Granted | 2007-08-21 | 2006-05-22 | 7259462 | 11419548 |
| Optical error minimization in a semiconductor manufacturing apparatus | United States of America | Lapsed | 2006-08-29 | 2005-03-07 | 7098996 | 11075195 |
| Optical error minimization in a semiconductor manufacturing apparatus | United States of America | Granted | 2007-11-20 | 2006-06-22 | 7298458 | 11473627 |
| Optical error minimization in a semiconductor manufacturing apparatus | United States of America | Lapsed | 2005-04-26 | 2002-09-13 | 6885436 | 10243562 |
| Low Dielectric Constant Fluorine and Carbon-Containing Silicon Oxide Dielectric Material Characterized by Improved Resistance to Oxidation | United States of America | Abandoned | | 2003-03-25 | | 10397993 |
| Process for forming a low dielectric constant fluorine and carbon containing silicon oxide dielectric material | United States of America | Granted | 2003-06-03 | 2001-02-23 | 6572925 | 09792683 |
| Method of fabricating a linearly continuous integrated circuit gate array | United States of America | Expired | 1998-06-30 | 1997-07-15 | 5773854 | 08892827 |
| Method of making an integrated circuit chip having an array of logic gates | United States of America | Expired | 1997-07-22 | 1996-06-11 | 5650348 | 08665016 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| MOS Transistor Having Aluminum Nitride Gate Structure And Method Of United States of America Manufacturing Same |
|---|
| MOS Transistor Having Aluminum Nitride Gate Structure And Method Of United States of America Manufacturing Same |
| Multi-step process for forming a barrier film for use in copper layer United States of America formation |
| Multi-step process for forming a barrier film for use in copper layer United States of America formation |
| Multi-step process for forming a barrier film for use in copper layer United States of America formation |
| United States of America capacitance |
| United States of America Capacitance |
| United States of America Hybrid Bump Capacitor |
| United States of America Hybrid Bump Capacitor |
| United States of America Method for growing thin films |
| United States of America Method for growing thin films |
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| United States of America Maskless |
| |
| United States of America Vortex Phase Shift Mask Applied to Optical Direct Write |
| United States of America Apparatus for confining inductively coupled surface currents |
| Apparatus to passivate inductively or capacitively coupled surface United States of America currents under capacitor structures |
| United States of America Apparatus For Confining Inductively Coupled Surface Currents |
| Techniques for forming passive devices during semiconductor back-end United States of America processing |
| Techniques for forming passive devices during semiconductor back-end United States of America processing |
| United States of America Bi-Axial Texturing Of High-K Dielectric Films To Reduce Leakage Currents |
| United States of America Bi-Axial Texturing Of High-K Dielectric Films To Reduce Leakage Currents |
| |

| l | The Charles of America | 0555 | 7009-17-77 | 3005-11-03 | 7635888 | 11265062 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Buried Channel Devices And A Process For Their Fabrication Simultaneously With Surface Channel Devices To Produce Transistors And Capacitors With Multiple Electrical Gate Oxides | United States of America | Abandoned | | 2004-02-24 | | 10786481 |
| Buried channel devices and a process for their fabrication simultaneously with surface channel devices to produce transistors and capacitors with erica multiple electrical gate oxides | United States of America | Granted | 2004-06-08 | 2001-12-13 | 6747318 | 10020304 |
| nerica Methods of Fabricating A Metal-Oxide-Metal Capacitor | United States of America | Granted | 2004-05-04 | 2002-02-21 | 6730601 | 10080186 |
| | United States of America | Granted | 2002-04-16 | 2000-08-31 | 6373087 | 09652479 |
| | United States of America | Granted | 2008-06-24 | 2005-01-06 | 7390680 | 11031564 |
| Method to selectively identify reliability risk die based on characteristics of local regions on the wafer | United States of America | Lapsed | 2005-04-12 | 2003-06-04 | 6880140 | 10454027 |
| lerica Silicon germanium CMOS channel | United States of America | Granted | 2003-04-08 | 2000-11-28 | 6544854 | 09724444 |
| | United States of America | Lapsed | 2005-12-20 | 2003-02-18 | 6977400 | 10368811 |
| Method and apparatus for detecting backside contamination during fabrication of a semiconductor wafer | United States of America | Lapsed | 2003-09-30 | 2002-05-03 | 6627466 | 10138742 |
| Method and apparatus for detecting backside contamination during fabrication of a semiconductor wafer | United States of America | Lapsed | 2005-09-13 | 2003-07-28 | 6943055 | 10628601 |
| Polymeric dielectric layers having low dielectric constants and improved adhesion to metal lines | United States of America | Expired | 2002-09-24 | 2000-07-10 | 6455934 | 09618211 |
| Polymeric dielectric layers having low dielectric constants and improved adhesion to metal lines | United States of America | Expired | 2000-09-19 | 1997-06-19 | 6121159 | 08879100 |
| Process For Fabricating A Projection Electron Lithography Mask And A Removable, Reuseable Cover For Use Therein | United States of America | Granted | 2002-04-16 | 2001-05-15 | 6372393 | 09854753 |
| Process For Fabricating A Projection Electron Lithography Mask And A Removable, Reuseable Cover For Use Therein | United States of America | Granted | 2001-06-26 | 1999-06-14 | 6251543 | 09332061 |
| erica Electron Emitters For Lithography Tools | United States of America | Granted | 2001-05-15 | 1999-05-06 | 6232040 | 09306287 |
| erica Electron Emitters For Lithography Tools | United States of America | Granted | 2002-06-04 | 2001-03-27 | 6400090 | 09818799 |
| erica Optimized Mirror Design For Optical Direct Write | United States of America | Lapsed | 2010-06-15 | 2007-06-27 | 7738078 | 11769486 |
| nerica New Optimized Mirror Design for Optical Direct Write | United States of America | Abandoned | | 1900-01-01 | | 60513780 |
| lerica Optimized mirror design for optical direct write | United States of America | Granted | 2007-09-18 | 2004-04-14 | 7270942 | 10825342 |
| nerica Method Of Electrical Testing | United States of America | Granted | 2006-11-07 | 2005-05-26 | 7132840 | 11138152 |
| Method Of Electrical Testing Of An Integrated Circuit With An Electrical Probe | United States of America | Granted | 2007-07-03 | 2006-09-29 | 7239160 | 11540056 |
| erica Ultra low dielectric constant thin film | United States of America | Lapsed | 2005-06-14 | 2003-10-22 | 6905909 | 10691400 |
| erica Ultra Low Dielectric Constant Thin Film | United States of America | Abandoned | | 2005-04-14 | | 11106307 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Vertical Replacement-Gate (VRG) Silicon-On-Insulator (SOI) CMOS Transistor | United States of America | Granted | 2004-03-23 | 2001-09-28 | 6709904 | 09968234 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Vertical Replacement-Gate Silicon-On-Insulator Transistor | United States of America | Granted | 2007-08-21 | 2006-05-19 | 7259048 | 11419356 |
| Vertical Replacement-Gate Silicon-On-Insulator Transistor | United States of America | Lapsed | 2006-07-18 | 2004-02-06 | 7078280 | 10773900 |
| Semiconductor Device Having A Doped Lattice Matching Layer And A Method Of Manufacture Therefor | United States of America | Granted | 2005-02-15 | 2004-03-31 | 6855991 | 10814680 |
| Semiconductor Device Having A Doped Lattice Matching Layer And A Method Of Manufacture Therefor | United States of America | Granted | 2004-05-18 | 2001-10-24 | 6737339 | 10003873 |
| Semiconductor Device Having A Doped Lattice Matching Layer And A Method Of Manufacture Therefor | United States of America | Abandoned | | 2004-03-31 | | 10814682 |
| Real-Time Gate Etch Critical Dimension Control By Oxygen Monitoring | United States of America | Granted | 2007-08-28 | 2003-09-30 | 7261745 | 10675572 |
| Real-Time Gate Etch Critical Dimension Control By Oxygen Monitoring | United States of America | Lapsed | 2009-12-15 | 2007-07-13 | 7632690 | 11827807 |
| Method For Fabricating A Merged Integrated Circuit Device | United States of America | Granted | 2003-09-30 | 2001-02-20 | 6627963 | 09789254 |
| A Method For Fabricating A Merged Integrated Circuit Device | United States of America | Granted | 2001-04-10 | 1999-02-08 | 6214675 | 09246402 |
| Voltage contrast monitor for integrated circuit defects | United States of America | Lapsed | 2008-01-29 | 2005-05-18 | 7323768 | 11131705 |
| Voltage contrast monitor for integrated circuit defects | United States of America | Lapsed | 2005-08-30 | 2003-08-29 | 6936920 | 10652369 |
| Voltage Contrast Monitor for Integrated Circuit Defects | United States of America | Lapsed | 2009-07-14 | 2007-11-08 | 7560292 | 11937199 |
| Semiconductor wafer having a layer-to-layer alignment mark and method for fabricating the same | United States of America | Granted | 2000-10-24 | 1999-05-13 | 6136662 | 09311253 |
| Semiconductor wafer having a layer-to-layer alignment mark and method for fabricating the same | United States of America | Granted | 2001-09-11 | 2000-06-23 | 6288454 | 09602797 |
| Bipolar Device Having Buried Contacts | United States of America | Lapsed | 2013-02-12 | 2011-08-31 | 8372723 | 13222877 |
| Bipolar Device Having Buried Contacts | United States of America | Lapsed | 2011-11-01 | 2006-09-21 | 8049282 | 11533785 |
| Barrier For Copper Metallization | United States of America | Granted | 2001-09-11 | 1998-12-22 | 6288449 | 09218649 |
| Barrier For Copper Metallization | United States of America | Granted | 2002-09-24 | 2000-11-28 | 6455418 | 09723557 |
| Semiconductor Device With Constricted Current Passage | United States of America | Lapsed | 2009-08-04 | 2007-10-15 | 7569445 | 11872347 |
| Semiconductor Device With Constricted Current Passage | United States of America | Granted | 2008-02-12 | 2003-04-01 | 7329926 | 10404832 |
| III/V Power Field Effect Transistors | United States of America | Granted | 2007-02-20 | 2004-09-24 | 7180103 | 10948897 |
| III-V Power Field Effect Transistors | United States of America | Lapsed | 2009-05-26 | 2006-12-19 | 7537984 | 11641507 |
| Process For Fabricating Vertical Transistors | United States of America | Granted | 2000-02-22 | 1998-08-28 | 6027975 | 09143274 |
| Process For Fabricating Vertical Transistors | United States of America | Granted | 2001-03-06 | 1999-06-18 | 6197641 | 09335707 |
| Ultra Thin Body Vertical Replacement Gate Mosfet | United States of America | Granted | 2003-10-21 | 2002-06-06 | 6635924 | 10164202 |
| Method Of Making Ultra Thin Body Vertical Replacement Gate Mosfet | United States of America | Granted | 2004-11-23 | 2003-08-27 | 6821851 | 10649140 |
| Interdigitated Capacitors | United States of America | Granted | 2011-10-18 | 2009-11-10 | 8039923 | 12616050 |
| Interdigitated Capacitors | United States of America | Granted | 4 | 2004-07-08 | 7022581 | 10886763 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Integrated Circuit Having Amorphous Silicide Layer In Contacts And Vias And Method Of Manufacture Therefor | United States of America | Expired | 2000-02-22 | 1998-05-06 | 6028359 | 09073556 |
|---|--------------------------|---------|------------|------------|----------|----------|
| Substrates and methods for gas phase deposition of semiconductors and othermaterials | United States of America | Expired | 1996-12-31 | 1995-06-07 | 5589693 | 08475110 |
| Substrates and Methods for Gas Phase Deposition of Semiconductors and Other Materials | United States of America | Expired | 1995-10-31 | 1994-11-29 | 5462012 | 08346444 |
| Semiconductor Device Having Aluminum Contacts Or Vias And Method Of Manufacture Therefor | United States of America | Expired | 2000-12-05 | 1998-10-05 | 6157082 | 09166832 |
| Semiconductor Device Having Aluminum Contacts Or Vias And Method Of Manufacture Therefor | United States of America | Expired | 1999-06-15 | 1997-03-18 | 5913146 | 08820063 |
| Mold For Non-Photolithographic Fabrication Of Microstructures | United States of America | Granted | 2001-11-27 | 1999-09-09 | 6322736 | 09393032 |
| Mold For Non-Photolithographic Fabrication Of Microstructures | United States of America | Granted | 2000-03-07 | 1998-03-27 | 6033202 | 09049531 |
| System And Method For Forming A High Quality Ultrathin Gate Oxide Layer | United States of America | Expired | 2001-08-28 | 1999-06-24 | 6281138 | 09338939 |
| System And Method For Forming A High Quality Ultrathin Gate Oxide Layer | United States of America | Expired | 2000-02-15 | 1997-04-28 | 6025280 | 08848109 |
| Method Of Creating an Interconnect In A Substrate And Semiconductor Device Employing The Same | United States of America | Granted | 2001-04-24 | 1999-10-27 | 6222255 | 09428073 |
| Method Of Creating An Interconnect In A Substrate And Semiconductor Device Employing The Same | United States of America | Granted | 2000-08-22 | 1997-11-07 | 6107191 | 08965706 |
| Method Of Making InP Heterostructure Devices | United States of America | Granted | 2000-12-26 | 1999-02-23 | 6165859 | 09255845 |
| InP Heterostructure Devices | United States of America | Granted | 1999-05-25 | 1998-05-01 | 5907165 | 09071006 |
| Reduced particulate etching | United States of America | Granted | 2003-06-10 | 2001-07-03 | 6576981 | 09898267 |
| Reduced particulate etching | United States of America | Granted | 2004-06-22 | 2003-03-27 | 6753268 | 10400310 |
| Method For Making Field Effect Devices And Capacitors With Improved Thin Film Dielectrics And Resulting Devices | United States of America | Granted | 1999-12-14 | 1998-04-15 | 6001741 | 09060420 |
| Method For Making Field Effect Devices And Capacitors With Thin Film Dielectrics And Resulting Devices | United States of America | Granted | 2001-09-04 | 1999-11-04 | 6284663 | 09434424 |
| Forming Copper Interconnects with SN Coatings | United States of America | Lapsed | 2010-03-09 | 2005-03-07 | 7675177 | 11074456 |
| Forming copper interconnects with Sn coatings | United States of America | Granted | 2005-04-26 | 2003-08-25 | 6884720 | 10648602 |
| Increased Quality Factor Of A Varactor In An Integrated Circuit Via A High Conductive Region In A Well | United States of America | Granted | 2004-11-30 | 2003-06-04 | 6825089 | 10454133 |
| Increased Quality Factor Of A Varactor In An Integrated Circuit Via A High Conductive Region In A Well | United States of America | Granted | 2008-03-18 | 2004-08-16 | 7345354 | 10918981 |
| A Spiral Inductor Formed In A Semiconductor Substrate And A Method For Forming The Inductor | United States of America | Lapsed | 2006-07-11 | 2003-08-22 | 7075167 | 10646997 |
| A Method Of Forming A Spiral Inductor In A Semiconductor Substrate | United States of America | Granted | 2008-06-03 | 2006-05-19 | 7381607 | 11419252 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Semiconductor Device Having An Interconnect Layer With A Plurality Of Layout Regions Having Substantially Uniform Densities Of Active Interconnects And Dummy Fills | United States of America | Granted | 2004-01-27 | 2002-05-16 | 6683382 | 10147384 |
|---|--------------------------|-----------|------------|------------|-----------|----------|
| Method For In-Situ Removal Of Side Walls In MOM Capacitor Formation | United States of America | Granted | 2003-12-02 | 2002-08-08 | 6656850 | 10215170 |
| Method For In-Situ Removal Of Side Walls In MOM Capacitor Formation | United States of America | Granted | 2002-10-01 | 1999-12-17 | 6458648 | 09466715 |
| Apparatus And Method For Determining Process Width Variations In Integrated Circuits | United States of America | Granted | 2004-04-27 | 2002-01-18 | 6728940 | 10053097 |
| Apparatus And Method For Determining Process Width Variations In Integrated Circuits | United States of America | Granted | 2002-04-16 | 2000-03-31 | 6373266 | 09540473 |
| Semiconductor wafer chuck assembly for a semiconductor processing device | United States of America | Granted | 2004-10-19 | 2003-06-13 | 6805338 | 10461255 |
| Semiconductor Wafer Chuck Assembly for a Semiconductor Processing Device | United States of America | Abandoned | | 2004-08-02 | | 10909821 |
| Self-timed reliability and yield vehicle with gated data and clock | United States of America | Granted | 2007-12-11 | 2004-07-27 | 7308627 | 10900642 |
| Self-timed reliability and yield vehicle array | United States of America | Lapsed | 2005-03-01 | 2003-04-16 | 6861864 | 10418560 |
| Method and Apparatus for Enhancing Image Contrast Using Intensity Filtration | United States of America | Abandoned | | 1998-06-29 | | 09106720 |
| Method and apparatus for enhancing image contrast using intensity filtration | United States of America | Lapsed | 2006-04-25 | 2003-02-18 | 7033710 | 10368812 |
| Method and apparatus for enhancing image contrast using intensity filtration | United States of America | Granted | 2003-04-15 | 2000-04-24 | 6549322 | 09557946 |
| Apparatus for enhancing image contrast using intensity filtration | United States of America | Granted | 2001-08-07 | 2000-12-15 | 6271911 | 09737504 |
| Integrated circuit isolation system | United States of America | Lapsed | 2004-12-14 | 2003-03-06 | 6831348 | 10383031 |
| Integrated circuit isolation system | United States of America | Lapsed | 2003-09-02 | 2000-09-05 | 6613651 | 09654689 |
| Trench Capacitors In Soi Substrates | United States of America | Granted | 2003-04-22 | 2002-02-05 | 6552381 | 10072500 |
| Method For Forming Trenches Capacitors In Soi Substrates | United States of America | Granted | 2002-05-14 | 2000-04-25 | 6387772 | 09557536 |
| Semiconductor Manufacturing Using Modular Substrates | United States of America | Granted | 2004-03-30 | 2002-11-25 | 6713409 | 10303280 |
| Modular Semiconductor Substrates | United States of America | Granted | 2003-03-18 | 2000-08-21 | 6534851 | 09642376 |
| Lens Array For Electron Beam Lithography Tool | United States of America | Granted | 2008-03-18 | 1999-10-07 | 7345290 | 09414004 |
| Illumination System For Electron Beam Lithography Tool | United States of America | Granted | 2001-12-25 | 2000-05-30 | 6333508 | 09580530 |
| Capacitor For Integration With Copper Damascene Processes And A Method Of Manufacture Therefore | United States of America | Granted | 2006-11-14 | 2002-07-16 | 7135733 | 10195935 |
| A Capacitor For Integration With Copper Damascene Processes | United States of America | Granted | 2002-12-24 | 2000-01-21 | 6498364 | 09489092 |
| Integrated Circuit Having Amorphous Silicide Layer In Contacts And Vias AndMethod Of Manufacture Therefor | United States of America | Expired | 1999-01-12 | 1997-03-12 | 5858873 | 08816185 |
| nuc | Country | Status | GrantDate | FiledDate | Patentivo | Aydya |

| 09724225 6521549 | 09661465 6489242 | 10253158 6713394 | 11939482 7670645 | 10697506 7323228 | 09956409 | 09665988 6553166 | 09594478 6300663 | 08791244 6117736 | 11014476 | 10360903 6874510 | 11098290 7129516 | 10418375 6982229 | 09502868 6329305 | 09861839 6475931 | 11736402 7728433 | 12764004 8043968 | 10414601 7276441 | 09484310 6436807 | AppNo PatentNo |
|---|--|--|---|--|------------------------------------|--|--|--|--|--|--|--|---|---|--|--|--|---|----------------|
| | | | | | | | | | | | | | | | | | | | |
| 2000-11-28 | 2000-09-13 | 2002-09-24 | 2007-11-13 | 2003-10-29 | 2001-09-19 | 2000-09-20 | 2000-06-15 | 1997-01-30 | 2004-12-16 | 2003-02-07 | 2005-04-04 | 2003-04-18 | 2000-02-11 | 2001-05-21 | 2007-04-17 | 2010-04-20 | 2003-04-15 | 2000-01-18 | FiledDate |
| 2003-02-18 | 2002-12-03 | 2004-03-30 | 2010-03-02 | 2008-01-29 | | 2003-04-22 | 2001-10-09 | 2000-09-12 | | 2005-04-05 | 2006-10-31 | 2006-01-03 | 2001-12-11 | 2002-11-05 | 2010-06-01 | 2011-10-25 | 2007-10-02 | 2002-08-20 | GrantDate |
| Granted | Granted | Granted | Lapsed | Granted | ned | Lapsed | Expired | Expired | Abandoned | Lapsed | Lapsed | Lapsed | Granted | Granted | Lapsed | Granted | Granted | Granted | Status |
| United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Country |
| Method of reducing silicon oxynitride gate insulator thickness in some transistors of a hybrid integrated circuit to obtain increased differential in gate insulator thickness with other transistors of the hybrid circuit | Process for planarization of integrated circuit structure which inhibits cracking of low dielectric constant dielectric material adjacent underlying raised structures | Process for planarization of integrated circuit structure which inhibits cracking of low dielectric constant dielectric material adjacent underlying raised structures | Method of Treating Metal and Metal Salts to Enable Thin Layer Deposition in Semiconductor Processing | Method of vaporizing and ionizing metals for use in semiconductor processing | Parallel Active Optical SCSI Cable | Concentric optical cable with full duplex connectors | Insulated-gate field-effect transistors having different gate capacitances | Method of fabricating insulated-gate field-effect transistors having different gate capacitances | Method to Use a Laser to Perform the Edge Clean Operation on a Semiconductor Wafer | Method to use a laser to perform the edge clean operation on a semiconductor wafer | lon recoil implantation and enhanced carrier mobility in CMOS device | lon recoil implantation and enhanced carrier mobility in CMOS device | Method For Producing Devices Having Piezoelectric Films | Method For Producing Devices Having Piezoelectric Films | Dielectric Barrier Layer For Increasing Electromigration Lifetimes In Copper Interconnect Structures | Dielectric Barrier Layer For Increasing Electromigration Lifetimes In Copper Interconnect Structures | Dielectric barrier layer for increasing electromigration lifetimes in copper interconnect structures | Method For Making An Interconnect Layer And A Semiconductor Device Including The Same | litte |

| Integrated circuit fabrication dual plasma process with separate introduction of different gases into gas flow | United States of America | Granted | 2003-11-04 | 2002-08-01 | 6641698 | 10210365 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Method of reducing process plasma damage using optical spectroscopy | United States of America | Lapsed | 2005-12-06 | 2003-10-06 | 6972840 | 10680503 |
| Impact of F Species on Plasma Charge Damage in a RF Aher | United States of America | Abandoned | | 1900-01-01 | | 60384499 |
| Method of reducing process plasma damage using optical spectroscopy | United States of America | Granted | 2004-01-06 | 2002-07-12 | 6673200 | 10195775 |
| Method of chemically altering a silicon surface and associated electrical devices | United States of America | Lapsed | 2004-11-23 | 2003-06-20 | 6822308 | 10600665 |
| Method of chemically altering a silicon surface and associated electrical devices | United States of America | Granted | 2003-09-30 | 2002-04-24 | 6627556 | 10131431 |
| Electro chemical mechanical polishing method and device for planarizing semiconductor surfaces | United States of America | Granted | 2007-10-23 | 2004-12-07 | 7285145 | 11007694 |
| Electro chemical mechanical polishing method | United States of America | Granted | 2005-02-22 | 2002-07-12 | 6858531 | 10195044 |
| Silicon nitride and silicon dioxide gate insulator transistors and method of forming same in a hybrid integrated circuit | United States of America | Granted | 2003-05-13 | 2002-06-14 | 6562729 | 10171700 |
| Silicon nitride and silicon dioxide gate insulator transistors and method of forming same in a hybrid integrated circuit | United States of America | Granted | 2002-08-20 | 2000-11-28 | 6436845 | 09723516 |
| Dielectric barrier films for use as copper barrier layers in semiconductor trench and via structures | United States of America | Granted | 2008-09-23 | 2005-05-16 | 7427563 | 11131003 |
| Dielectric barrier films for use as copper barrier layers in semiconductor trench and via structures | United States of America | Lapsed | 2005-09-06 | 2002-12-16 | 6939800 | 10321938 |
| Dielectric Barrier Films For Use As Copper Barrier Layers In Semiconductor Trench And Via Structures | United States of America | Granted | 2010-01-12 | 2008-08-13 | 7646077 | 12191171 |
| Capacitor having a tantalum lower electrode and method of forming the same | United States of America | Lapsed | 2005-03-01 | 2002-08-27 | 6861310 | 10228859 |
| Capacitor having a tantalum lower electrode and method of forming the same | United States of America | Lapsed | 2002-11-12 | 2000-03-02 | 6479857 | 09517150 |
| Method and apparatus for planarizing a wafer surface of a semiconductor wafer having an elevated portion extending therefrom | United States of America | Granted | 2002-09-17 | 1999-07-30 | 6451699 | 09364140 |
| Method and apparatus for planarizing a wafer surface of a semiconductor wafer having an elevated portion extending therefrom | United States of America | Granted | 2003-05-20 | 2002-07-25 | 6566268 | 10205229 |
| Method of reducing silicon oxynitride gate insulator thickness in some transistors of a hybrid integrated circuit to obtain increased differential in gate insulator thickness with other transistors of the hybrid circuit | United States of America | Lapsed | 2003-12-02 | 2002-11-26 | 6656805 | 10304631 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method and apparatus for removing photoresist edge beads from thin film substrates | United States of America | Granted | 2002-12-17 | 2001-06-12 | 6495312 | 09879642 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| Method For Creating Barriers For Copper Diffusion | United States of America | Granted | 2010-11-09 | 2005-04-12 | 7829455 | 11104763 |
| Method for creating barriers for copper diffusion | United States of America | Lapsed | 2006-10-03 | 2001-10-22 | 7115991 | 10044864 |
| Integrated circuit process monitoring and metrology system | United States of America | Lapsed | 2006-10-03 | 2005-03-04 | 7115425 | 11072127 |
| Integrated circuit process monitoring and metrology system | United States of America | Lapsed | 2005-11-15 | 2001-09-11 | 6964924 | 09952790 |
| Exhaust flow control system | United States of America | Granted | 2003-06-17 | 2000-09-20 | 6579371 | 09666507 |
| Exhaust flow control system | United States of America | Granted | 2004-09-07 | 2002-07-17 | 6787180 | 10196787 |
| Method of manufacturing a shallow trench isolation structure with low trench parasitic capacitance | United States of America | Lapsed | 2006-02-21 | 2001-11-14 | 7001823 | 09991202 |
| Shallow Trench Isolation Structure With Low Trench Parasitic Capacitance | United States of America | Lapsed | 2009-11-17 | 2005-10-28 | 7619294 | 11262173 |
| Method Characterizing Materials For A Trench Isolation Structure Having Low Trench Parasitic Capacitance | United States of America | Granted | 2011-09-20 | 2009-10-06 | 8021955 | 12574426 |
| Method for preventing borderless contact to well leakage | United States of America | Granted | 2003-04-22 | 2001-11-30 | 6551901 | 10006540 |
| Semiconductor chip with borderless contact that avoids well leakage | United States of America | Lapsed | 2006-08-29 | 2005-04-11 | 7098515 | 11104050 |
| Method for preventing borderless contact to well leakage | United States of America | Granted | 2005-05-17 | 2003-02-05 | 6893937 | 10360746 |
| Process Enhancement to Prevent LI or Borderless Contact To Well Leakage | United States of America | Abandoned | | 1900-01-01 | | 60314148 |
| Dual Gate Oxide Process for Deep Submicron ICS | United States of America | Abandoned | | 2001-12-21 | | 10026282 |
| Dual gate oxide process for deep submicron ICS | United States of America | Granted | 2002-03-19 | 1998-12-15 | 6358819 | 09212315 |
| Shallow junction formation | United States of America | Granted | 2003-08-12 | 2002-10-10 | 6605846 | 10268736 |
| Shallow junction formation | United States of America | Granted | 2002-11-26 | 2000-09-26 | 6486064 | 09670448 |
| Adjustable transmission phase shift mask | United States of America | Lapsed | 2005-01-11 | 2001-11-09 | 6841308 | 10039508 |
| Adjustable transmission phase shift mask | United States of America | Lapsed | 2006-06-27 | 2004-10-25 | 7067223 | 10972898 |
| Adjustable Transmission Phase Shift Mask | United States of America | Abandoned | | 2006-05-03 | | 11381409 |
| Method and apparatus for determining temperature of a semiconductor wafer during fabrication thereof | United States of America | Granted | 2004-09-21 | 2001-09-14 | 6794310 | 09952540 |
| Method and apparatus for determining temperature of a semiconductor wafer during fabrication thereof | United States of America | Granted | 2001-12-11 | 1999-09-14 | 6328802 | 09395507 |
| Low via resistance system | United States of America | Granted | 2005-05-17 | 2003-03-27 | 6893962 | 10400252 |
| Low via resistance system | United States of America | Granted | 2003-05-27 | 2000-07-17 | 6569751 | 09617550 |
| Substrate laser marking | United States of America | Granted | 2008-05-13 | 2001-12-12 | 7371659 | 10020764 |
| Laser Marking Hole Shape Of Semiconductor Wafer | United States of America | Abandoned | | 2008-02-21 | | 12034750 |
| Integrated circuit fabrication dual plasma process with separate introduction of different gases into gas flow | United States of America | Granted | 2002-10-08 | 2000-12-22 | 6461972 | 09747638 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method Of Forming Metal Oxide Metal Capacitors Using Multi-Step Rapid Thermal Process And A Device Formed Thereby | United States of America | Granted | 2002-12-17 | 2001-09-25 | 6495875 | 09962641 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Method of preventing resist poisoning in dual damascene structures | United States of America | Granted | 2004-03-30 | 2001-12-19 | 6713386 | 10025304 |
| Method of preventing resist poisoning in dual damascene structures | United States of America | Granted | 2005-11-29 | 2003-12-31 | 6969683 | 10750348 |
| Method of Making Multilayered A1-alloy Structure For Metal Conductors | United States of America | Expired | 1996-10-01 | 1994-12-29 | 5561083 | 08365652 |
| Multilayered Al-alloy Structure For Metal Conductors | United States of America | Expired | 1997-06-24 | 1996-06-26 | 5641994 | 08668310 |
| Process For Forming Isolation Regions In An Integrated Circuit | United States of America | Expired | 1998-06-09 | 1996-03-22 | 5763314 | 08620964 |
| Process for Forming Isolation Regions in An Integrated Circuit and Structure Formed Thereby | United States of America | Granted | 2002-09-03 | 1994-11-30 | 6445043 | 08347527 |
| A Thin Film Resistor Device And A Method Of Manufacture Therefor | United States of America | Granted | 2004-03-09 | 2000-07-12 | 6703666 | 09614992 |
| A Thin Film Resistor Device And A Method Of Manufacture Therefor | United States of America | Granted | 2007-10-02 | 2004-01-22 | 7276767 | 10762962 |
| Integrated Circuit Device Substrates With Selective Epitaxial Growth Thickness Compensation | United States of America | Granted | 2004-04-27 | 2002-03-05 | 6727567 | 10091291 |
| Manufacture Of Dielectrically Isolated Integrated Circuits | United States of America | Granted | 2002-06-25 | 1999-12-15 | 6409829 | 09461609 |
| Polishing Fluid, Polishing Method, Semiconductor Device And Semiconductor Device Fabrication Method | United States of America | Granted | 2001-12-11 | 2000-01-14 | 6328633 | 09483785 |
| Polishing Fluid, Polishing Method, Semiconductor Device And Semiconductor Device Fabrication Method | United States of America | Granted | 2002-08-27 | 2001-06-28 | 6439972 | 09894117 |
| Semiconductor Device Structure Including A Tantalum Pentoxide Layer Sandwiched Between Silicon Nitride Layers | United States of America | Granted | 2001-09-25 | 1999-02-26 | 6294807 | 09259001 |
| Semiconductor Device Structure Including A Tantalum Pentoxide Layer Sandwiched Between Silicon Nitride Layers | United States of America | Granted | 2002-11-19 | 2001-06-11 | 6482694 | 09878657 |
| A Method Of Eliminating Agglomerate Particles In A Polishing Slurry | United States of America | Granted | 2004-06-15 | 2001-11-14 | 6750145 | 09992135 |
| A Method Of Eliminating Agglomerate Particles In A Polishing Slurry | United States of America | Granted | 2002-03-12 | 1999-10-26 | 6355184 | 09427306 |
| Method Of Eliminating Agglomerate Particles In A Polishing Slurry | United States of America | Granted | 2000-02-15 | 1998-05-21 | 6024829 | 09083072 |
| Metal\\(miOxide Semiconductor Device Having Improved Performance And Reliability. | United States of America | Granted | 2008-02-26 | 2006-02-07 | 7335565 | 11348597 |
| Metal-Oxide Semiconductor Device Having Improved Performance And Reliability. | United States of America | Lapsed | 2006-02-28 | 2003-10-17 | 7005703 | 10688231 |
| Dual\(miGate Metal\(miOxide Semiconductor Device | United States of America | Granted | 2008-02-12 | 2004-11-30 | 7329922 | 10999705 |
| Dual-Gate Metal-Oxide Semiconductor Device | United States of America | Lapsed | 2009-08-25 | 2007-10-30 | 7579245 | 11927950 |
| Method and Apparatus for Removing Photoresist Edge Beads From Thin Film Substrates | United States of America | Abandoned | | 2001-02-01 | | 09775223 |
| Apparatus for removing photoresist edge beads from thin film substrates | United States of America | Granted | 2003-09-02 | 2002-10-03 | 6614507 | 10263593 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 09386592 | 08848113 | 08862226 | 09015981 | 09523782 | 10038734 | 10218783 | 09578082 | 09338143 | 09886780 | 09572060 | 10003871 | 09940126 | 11403750 | 10953292 | 11458270 | 13026528 | 10953894 | 12727304 | 12243137 | 09418106 | AppNo |
|--|--|--|---|--|--|--|--|--|---|--|--|--|---|---|--|--|--|--|--|---|-----------|
| 6309938 | 5982020 | 5731626 | 6153920 | 6362054 | 6762459 | 6833286 | 6465884 | 6255714 | 6649422 | 6383879 | 6579775 | 6573149 | 7388395 | 7061264 | 7449388 | 8143120 | 7095094 | 7910425 | 7713811 | 6323078 | PatentNo |
| 1999-08-31 | 1997-04-28 | 1997-05-23 | 1998-01-30 | 2000-03-13 | 2001-12-31 | 2002-08-14 | 2000-05-24 | 1999-06-22 | 2001-06-21 | 2000-05-17 | 2001-10-24 | 2001-08-27 | 2006-04-13 | 2004-09-29 | 2006-07-18 | 2011-02-14 | 2004-09-29 | 2010-03-19 | 2008-10-01 | 1999-10-14 | FiledDate |
| 2001-10-30 | 1999-11-09 | 1998-03-24 | 2000-11-28 | 2002-03-26 | 2004-07-13 | 2004-12-21 | 2002-10-15 | 2001-07-03 | 2003-11-18 | 2002-05-07 | 2003-06-17 | 2003-06-03 | 2008-06-17 | 2006-06-13 | 2008-11-11 | 2012-03-27 | 2006-08-22 | 2011-03-22 | 2010-05-11 | 2001-11-27 | GrantDate |
| Expired | Expired | Expired | Expired | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Granted | Lapsed | Lapsed | Granted | Lapsed | Granted | Lapsed | Granted | Status |
| United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | Country |
| Deuterated Bipolar Transistors And Method Of Manufacture Thereof | Deuterated Bipolar Transistors And Method Of Manufacture Thereof | Process For Controlling Dopant Diffusion In A Semiconductor Layer And Semiconductor Layer Formed Thereby | A Semiconductor Device Configured to Control Dopant Diffusion In the Semiconductor Device Substrate | Method For Fabricating MOS Device With Halo Implanted Region | Method For Fabricating MOS Device With Halo Implanted Region | Semiconductor Device With Variable Pin Locations | Semiconductor Device With Variable Pin Locations | An Integrated Circuit Having A Micromagnetic Device And Method Of Manufacture Therefor | Integrated Circuit Having A Micromagnetic Device And Method Of Manufacture Therefor | A Semconductor Device Having A Metal Gate With A Work Function Compatible With A Semiconductor Device | A Semconductor Device Having A Metal Gate With A Work Function Compatible With A Semiconductor Device | A Semconductor Device Having A Metal Gate With A Work Function Compatible With A Semiconductor Device | Test Semiconductor Device And Method For Determining Joule Heating Effects In Such A Device | Test Semiconductor Device And Method For Determining Joule Heating Effects In Such A Device | Method For Forming Multiple Doping Level Bipolar Junctions Transistors | Multiple Doping Level Bipolar Junctions Transistors And Method For Forming | Multiple Doping Level Bipolar Junctions Transistors And Method For Forming | Multiple Doping Level Bipolar Junctions Transistors And Method For Forming | Multiple Doping Level Bipolar Junctions Transistors And Method For Forming | A Method Of Forming Metal Oxide Metal Capacitors Using Multi-Step Rapid Thermal Process And A Device Formed Thereby | litte |

| Process F |
|---|
| United States of America Phase-Shifting Mask And Semiconductor Device United States of America Thin Film Deposition Of Mixed Metal Oxides |
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| United States of America Phase-Shifting Mask And Semiconductor Device |
| Process For Oxide Fabrication Using Oxidation Steps Below And Above A United States of America Threshold Temperature |
| Two-Step Oxidation Process For Oxidizing A Silicon Substrate Wherein The First Step Is Carried Out At A Temperature Below The Viscoelastic Temperature Of Silicon Dioxide And The Second Step Is Carried Out At A United States of America Temperature Above The Viscoelastic Temperature |
| United States of America Temperature |
| Two-Step Oxidation Process For Oxidizing A Silicon Substrate Wherein The First Step Is Carried Out At A Temperature Below The Viscoelastic Temperature Of Silicon Dioxide And The Second Step Is Carried Out At A Temperature Above The Viscoelastic |
| Method Of Forming An Alignment Feature In Or On A Multi-Layered United States of America Semiconductor Structure |
| United States of America Multi-Layered Semiconductor Structure |
| A Method Of Forming An United States of America Semiconductor Structure |
| United States of America Guard Ring For Improved Matching |
| United States of America Guard Ring For Improved Matching |
| Optical Probe Microscope Having A Fiber Optic Tip That Receives Both A Dither Motion And A Scanning Motion, For Nondestructive Metrology Of United States of America Large Sample Surfaces |
| Optical Probe Microscope Having A Fiber Optic Tip That Receives Both A Dither Motion And A Scanning Motion, For Nondestructive Metrology Of United States of America Large Sample Surfaces |
| United States of America On-Chip Vacuum Tube Device And Process For Making Device |
| America Process For Making An On-Chip Vacuum Tube Device |
| Process For Fabricating Improved Iron-Cobalt Magnetostrictive Alloy And United States of America Article Comprising Alloy |
| Process For Fabricating Improved Iron-Cobalt Magnetostrictive Alloy And United States of America Article Comprising Alloy |
| Title |

| Method For Making A Capacitor | United States of America | Expired | 1998-12-22 | 1996-05-09 | 5851870 | 08644086 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| Method for Making A Metal to metal Capacitor | United States of America | Expired | 1996-11-19 | 1994-12-09 | 5576240 | 08353015 |
| Arrangement And Method For Abating Effluent From A Process | United States of America | Lapsed | 2009-08-25 | 2001-08-29 | 7578883 | 09942330 |
| Arrangement And Method For Abating Effluent From A Process | United States of America | Granted | 2012-01-17 | 2009-07-13 | 8097179 | 12502057 |
| Detecting Defects In Integrated Circuits | United States of America | Expired | 2000-03-28 | 1998-01-02 | 6043662 | 09002497 |
| Detecting Breakdown In Dielectric Layers | United States of America | Expired | 1998-09-08 | 1996-09-18 | 5804975 | 08718113 |
| A Micromagnetic Device For Power Processing Applications And Method Of Manufacture Therefor | United States of America | Expired | 2000-12-12 | 2000-01-24 | 6160721 | 09490655 |
| A Micromagnetic Device For Data Transmission Applications And Method Of Manufacture Therefor | United States of America | Expired | 2000-12-19 | 1998-07-02 | 6163234 | 09109963 |
| Integrated Circuit Having A Micromagnetic Device And Method Of Manufacture Therefor | United States of America | Expired | 2004-02-24 | 2001-10-15 | 6696744 | 09978871 |
| Micromagnetic Device For Power Processing Applications And Method Of Manufacture Therefor | United States of America | Lapsed | 2006-04-04 | 2003-03-13 | 7021518 | 10387846 |
| Method Of Making Integrated Circuit Having A Micromagnetic Device | United States of America | Expired | 2002-08-27 | 2000-02-23 | 6440750 | 09511343 |
| Micromagnetic Device Having An Anisotropic Ferromagnetic Core and Method of Manufacture Therefor | United States of America | Expired | 2001-02-20 | 1999-04-16 | 6191495 | 09292860 |
| A Micromagnetic Device For Power Processing Applications And Method Of Manufacture Therefor | United States of America | Expired | 2000-09-12 | 1997-06-10 | 6118351 | 08872250 |
| Compound, High-K, Gate And Capacitor Insulator Layer | United States of America | Granted | 2003-04-15 | 1997-12-22 | 6548854 | 08995435 |
| A Gate Stack Structure For Integrated Circuit Fabrication | United States of America | Granted | 2001-11-20 | 1999-06-25 | 6320238 | 09339895 |
| Hybrid Inorganic\(miOrganic Composite For Use As An Interlayer Dielectric | United States of America | Expired | 1999-10-12 | 1997-08-14 | 5965202 | 08911489 |
| Hybrid Inorganic\(miOrganic Composite For Use As An Interlayer Dielectric | United States of America | Expired | 2001-02-13 | 1999-03-27 | 6187427 | 09276912 |
| Device Comprising N-Channel Semiconductor Material | United States of America | Granted | 2002-05-14 | 2000-01-03 | 6387727 | 09476511 |
| Device Comprising N-Channel Semiconductor Material | United States of America | Granted | 2001-06-26 | 1999-03-29 | 6252245 | 09280103 |
| Thin Film Transistors | United States of America | Granted | 2001-05-15 | 1999-11-29 | 6232157 | 09450522 |
| Thin Film Transistors | United States of America | Granted | 2001-04-10 | 1998-08-20 | 6215130 | 09137920 |
| Structure And Fabrication Method For Capacitors Integratible With Vertical Replacement Gate Transistors | United States of America | Granted | 2011-03-22 | 2009-11-02 | 7911006 | 12610733 |
| An Integratible Vertical Replacement Gate (VRG)-type Poly-Nitride-Poly (PNP) Or Metal-Nitride-poly (MNP) Capacitor | United States of America | Abandoned | | 2001-09-18 | | 09956381 |
| Fabrication Method | United States of America | Granted | 2009-02-17 | 2007-06-01 | 7491610 | 11809873 |
| Method of Fabricating a Vertical Transistor and Capacitor | United States of America | Lapsed | 2010-04-20 | 2009-01-09 | 7700432 | 12319603 |
| Structure And Fabrication Method For Capacitors Integratible With Vertical Replacement Gate Transistors | United States of America | Lapsed | 2009-12-15 | 2007-05-31 | 7633118 | 11809686 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Consistent alignment mark profiles on semiconductor wafers using fine grain tungsten protective layer | United States of America | Expired | 1999-11-09 | 1997-09-08 | 5981352 | 08924903 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Method of detecting spatially correlated variations in a parameter of an integrated circuit die | United States of America | Granted | 2004-09-07 | 2001-12-12 | 6787379 | 10020407 |
| Method of detecting spatially correlated variations in a parameter of an integrated circuit die | United States of America | Lapsed | 2005-09-13 | 2003-08-13 | 6943042 | 10640778 |
| Method and composition for reducing gate oxide damage during RF sputter clean | United States of America | Granted | 2001-03-20 | 1999-02-17 | 6204550 | 09251702 |
| Method and composition for reducing gate oxide damage during RF sputter clean | United States of America | Granted | 1999-11-30 | 1997-11-21 | 5994211 | 08976033 |
| Method and apparatus for using across wafer back pressure differentials to influence the performance of chemical mechanical polishing | United States of America | Granted | 2003-03-11 | 1998-01-09 | 6531397 | 09005364 |
| Method and apparatus for using across wafer back pressure differentials to influence the performance of chemical mechanical polishing | United States of America | Granted | 2001-01-30 | 1999-11-16 | 6179956 | 09442078 |
| Shallow trench isolation chemical-mechanical polishing process | United States of America | Granted | 2002-07-23 | 2000-02-18 | 6424019 | 09507042 |
| Method for shallow trench isolations with chemical-mechanical polishing | United States of America | Granted | 2000-05-09 | 1998-06-16 | 6060370 | 09098635 |
| Apparatus and Method for Planarizing the Surface of a Semiconductor Wafer | United States of America | Abandoned | | 2003-01-03 | | 10336444 |
| Apparatus and method for planarizing the surface of a semiconductor wafer | United States of America | Granted | 2003-04-01 | 2000-06-29 | 6541383 | 09607169 |
| Carbon-doped hard mask and method of passivating structures during semiconductor device fabrication | United States of America | Granted | 2005-01-25 | 2003-04-02 | 6846569 | 10405666 |
| Carbon-doped hard mask and method of passivating structures during semiconductor device fabrication | United States of America | Granted | 2003-06-10 | 2000-12-19 | 6576404 | 09741568 |
| Process for making integrated circuit structure with thin dielectric between at least local interconnect level and first metal interconnect level | United States of America | Granted | 2002-11-26 | 2001-02-22 | 6486056 | 09790821 |
| Integrated circuit structure with thin dielectric between at least local interconnect level and first metal interconnect level, and process for making same | United States of America | Granted | 2001-05-29 | 1998-05-18 | 6239491 | 09081403 |
| An Electronic Component For An Integrated Circuit | United States of America | Expired | 1998-10-20 | 1997-05-27 | 5825073 | 08863713 |
| A Device and Method of Forming A Metal To Metal Capacitor Within an Integrated Circuit | United States of America | Expired | 2000-03-21 | 1997-08-12 | 6040616 | 08909563 |
| Integrated Circuit Capacitor | United States of America | Expired | 1997-08-05 | 1995-06-06 | 5654581 | 08472033 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method and apparatus for deposition of porous silica dielectrics | United States of America | Granted | 2001-09-11 | 1999-04-30 | 6287987 | 09302832 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| Method and Apparatus for Deposition of Porous Silica Dielectrics | United States of America | Abandoned | | 2001-05-23 | | 09863979 |
| Method and apparatus for detecting a planarized outer layer of a semiconductor wafer with a confocal optical system | United States of America | Granted | 2002-03-12 | 2001-01-04 | 6354908 | 09754429 |
| Method and apparatus for detecting a planarized outer layer of a semiconductor wafer with a confocal optical system | United States of America | Granted | 2001-03-13 | 1998-10-22 | 6201253 | 09177335 |
| Swapped drain structures for electrostatic discharge protection | United States of America | Granted | 2003-07-01 | 2001-12-20 | 6587322 | 10026186 |
| Swapped drain structures for electrostatic discharge protection | United States of America | Granted | 2002-03-19 | 1999-09-02 | 6359314 | 09388727 |
| Method to obtain a low resistivity and conformity chemical vapor deposition titanium film | United States of America | Expired | 2001-10-02 | 1998-12-22 | 6297555 | 09218780 |
| Method to obtain a low resistivity and conformity chemical vapor deposition titanium film | United States of America | Expired | 1999-04-20 | 1997-07-09 | 5895267 | 08889839 |
| Use of corrosion inhibiting compounds to inhibit corrosion of metal plugs in chemical-mechanical polishing | United States of America | Expired | 2000-05-30 | 1997-08-26 | 6068879 | 08918360 |
| Use of corrosion inhibiting compounds to inhibit corrosion of metal plugs in chemical-mechanical polishing | United States of America | Expired | 2002-05-07 | 2000-03-15 | 6383414 | 09526101 |
| Functional OBIC analysis | United States of America | Expired | 2000-11-28 | 1999-02-03 | 6154039 | 09244327 |
| Functional OBIC analysis | United States of America | Expired | 1999-05-18 | 1996-08-22 | 5905381 | 08701476 |
| Integrated circuit with isolation of field oxidation by noble gas implantation | United States of America | Expired | 2000-07-25 | 1997-08-19 | 6093936 | 08918577 |
| Integrated Circuit With Isolation Of Field Oxidation By Noble Gas Implantation And Method Of Making Such An Integrated Circuit. | United States of America | Abandoned | | 1996-04-29 | | 08641027 |
| Integrated Circuit With Isolation Of Field Oxidation By Nobel Gas Implantation And Method Of Making Such An Integrated Circuit | United States of America | Abandoned | | 1995-06-07 | | 08479104 |
| Integrated Circuit With Isolation Of Field Oxidation By Noble Gas Implantation And Method Of Making Such An Integrated Circuit | United States of America | Abandoned | | 1997-05-22 | | 08861899 |
| Metal-insulator-metal capacitor formed by damascene processes between metal interconnect layers and method of forming same | United States of America | Granted | 2003-02-25 | 2000-11-27 | 6524926 | 09723434 |
| Metal-insulator-metal capacitor formed by damascene processes between metal interconnect layers and method of forming same | United States of America | Granted | 2005-05-10 | 2002-11-26 | 6891219 | 10306011 |
| Consistent alignment mark profiles on semiconductor wafers using metal organic chemical vapor deposition titanium nitride protective layer | United States of America | Expired | 2000-12-05 | 1999-04-12 | 6157087 | 09289828 |
| Consistent alignment mark profiles on semiconductor wafers using metal organic chemical vapor deposition titanium nitride protective | United States of America | Expired | 1999-10-12 | 1997-09-08 | 5966613 | 08925200 |
| Consistent alignment mark profiles on semiconductor wafers using fine grain tungsten protective layer | United States of America | Expired | 2000-05-09 | 1999-07-27 | 6060787 | 09361684 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Well formation For CMOS devices integrated circuit structures | United States of America | Granted | 2000-11-07 | 1998-12-08 | 6144076 | 09207395 |
|---|--------------------------|-----------|------------|------------|----------|------------|
| Mask having an arbitrary complex transmission function | United States of America | Granted | 2001-03-06 | 1999-01-19 | 6197456 | 09233828 |
| Process for treating exposed surfaces of a low dielectric constant carbon doped silicon oxide dielectric material to protect the material from damage | United States of America | Granted | 2000-09-05 | 1999-07-27 | 6114259 | 09362645 |
| Low dielectric constant multiple carbon-containing silicon oxide dielectric material for use in integrated circuit structures, and method of making same | United States of America | Granted | 2001-10-16 | 1999-03-22 | 6303047 | 09274457 |
| Mask Having An Arbitrary Complex Transmission Function | Japan | Lapsed | 2011-09-30 | 2002-07-19 | 4831802 | 2001554123 |
| Plasma cleaning process for openings formed in at least one low dielectric constant insulation layer over copper metallization in integrated circuit structures | United States of America | Granted | 2001-03-20 | 1999-03-29 | 6204192 | 09281602 |
| Low Dielectric Constant Multiple Carbon-Containing Silicon Oxide Dielectric Material For Use In Integrated Circuit Structures, And Method Of Making Same | Japan | Lapsed | 2003-05-23 | 2000-03-22 | 3432783 | 2000079900 |
| Transistor Fabrication Method | United States of America | Granted | 2011-10-04 | 2010-01-19 | 8030199 | 12689749 |
| Transistor Fabrication Method | United States of America | Abandoned | | 2002-08-20 | | 10224220 |
| Transistor Fabrication Method | United States of America | Abandoned | | 2008-05-02 | | 12114589 |
| Transistor Fabrication Method | United States of America | Expired | 2002-12-24 | 1996-01-16 | 6498080 | 08587061 |
| Transistor Fabrication Method | United States of America | Expired | 1999-04-06 | 1995-04-27 | 5891784 | 08430084 |
| Shallow Trench Isolation Structures And A Method For Forming Shallow Trench Isolation Structures | United States of America | Granted | 2011-03-15 | 2007-10-29 | 7906407 | 11926469 |
| Shallow Trench Isolation Structures And A Method For Forming Shallow Trench Isolation Structures | United States of America | Abandoned | | 2005-09-19 | | 11230188 |
| Logic-Based eDRAM Using Local Interconnects to Reduce Impact of Extension Contact Parasitics | United States of America | Granted | 2012-10-09 | 2011-03-14 | 8283713 | 13046973 |
| CUB eDRAM cell with local Interconnects to reduce stacked contact parasitics Impact | United States of America | Expired | | 2010-06-02 | | 61350494 |
| Method for Improved Gate Oxide Integrity on Bulk Silicon | United States of America | Abandoned | | 1996-09-30 | | 08720514 |
| Method for improved gate oxide integrity on bulk silicon | United States of America | Expired | 2000-08-01 | 1997-10-20 | 6096625 | 08954006 |
| Semiconductor device with a pair of transistors having dual work function gate electrodes | United States of America | Granted | 2003-02-04 | 2000-06-09 | 6514824 | 09591108 |
| Semiconductor device with a pair of transistors having dual work function gate electrodes | United States of America | Granted | 2001-04-03 | 1998-09-29 | 6211555 | 09162407 |
| Method for composing a dielectric layer within an interconnect structure of a multilayer semiconductor device | United States of America | Lapsed | 2003-09-02 | 1998-09-30 | 6614097 | 09164069 |
| Method for composing a dielectric layer within an interconnect structure of a multilayer semiconductor device | United States of America | Lapsed | 2004-10-19 | 2003-06-11 | 6806162 | 10459072 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Alignment mark contrast enhancement | United States of America | Expired | 1999-01-26 | 1997-09-29 | 5863825 | 08940156 |
|---|-----------------------------|----------|------------|------------|----------|---------------|
| Method to improve uniformity/planarity on the edge die and also remove the tungsten stringers from wafer chemi-mechanical polishing | United States of America | Expired | 1999-09-28 | 1996-12-23 | 5960305 | 08771472 |
| System and method for preventing smoke and fire damage to people and equipment in a clean room area from a fire | United States of America | Expired | 1999-11-23 | 1997-07-24 | 5990789 | 08899629 |
| Semiconductor integrated circuit failure analysis using magnetic imaging | United States of America | Expired | 2000-05-16 | 1997-07-29 | 6064220 | 08902343 |
| Semiconductor die having sacrificial bond pads for die test | United States of America | Expired | 1999-07-13 | 1997-04-21 | 5923047 | 08837618 |
| Shaping polishing pad to control material removal rate selectively | United States of America | Expired | 1999-08-24 | 1997-08-25 | 5941761 | 08921758 |
| Method and apparatus for concurrent pad conditioning and wafer buff in chemical mechanical polishing | United States of America | Expired | 2001-05-22 | 1997-10-01 | 6234883 | 08942006 |
| Use of hydrofluoric acid for effective pad conditioning | United States of America | Expired | 1999-06-22 | 1997-08-27 | 5913715 | 08924493 |
| Chemical-mechanical polishing pad conditioning systems | United States of America | Expired | 2000-07-25 | 1997-08-18 | 6093280 | 08912597 |
| Controlling groove dimensions for enhanced slurry flow | United States of America | Expired | 1999-03-30 | 1997-09-23 | 5888121 | 08935584 |
| Through-pad drainage of slurry during chemical mechanical polishing | United States of America | Expired | 2004-02-17 | 1997-07-23 | 6692338 | 08899464 |
| Method and apparatus for agitating an etchant | United States of America | Expired | 2000-04-25 | 1997-10-06 | 6054062 | 08944247 |
| Process for forming self-aligned metal silicide contacts for MOS structure using single silicide-forming step | United States of America | Expired | 1999-09-14 | 1997-10-09 | 5953614 | 08947742 |
| Silicide encapsulation of polysilicon gate and interconnect | United States of America | Granted | 2001-04-17 | 1997-12-22 | 6218276 | 08995875 |
| Method of forming variable thickness gate dielectrics | United States of America | Granted | 2000-03-07 | 1998-03-09 | 6033998 | 09038684 |
| Electro-static discharge protection of CMOS integrated circuits | United States of America | Granted | 2000-03-28 | 1997-11-26 | 6043539 | 08978979 |
| Polishing | Japan | Granted | 2010-11-05 | 1997-12-24 | 4620189 | 1997355616 |
| A Novel Method To Improve Uniformity/Planarity On The Edge Die And Also Remove The Tungsten Stringers From Wafer Chemi-Mechanical | | | | | | |
| Reticle based skew lots | United States of America | Granted | 2000-10-10 | 1998-03-19 | 6130173 | 09045738 |
| Mirror Train | Japan | Lapsed | 2007-12-14 | 1997-11-26 | 4054424 | 09340704 |
| Method And Annaratic Of Fourier Manipulation in An Ontic Lens Or | Office States of Afficility | Gidillen | 01-/0-T0 | 1333-03-10 | 4108020 | 032001/4 |
| Top surface imaging technique using a topcoat delivery system | United States of America | Granted | 2001-07-10 | 1999-03-10 | 6258517 | 09366174 |
| Anti-microbubble denocition apparatus | United States of America | Granted | 2001-10-03 | 1000 OF 78 | 6276270 | 09321659 |
| Anti-airlock apparatus for filters | United States of America | Granted | 2001-10-09 | 1999-05-78 | 6799773 | 09371659 |
| Performance monitoring circuitry for integrated circuits | United States of America | | 2001-02-06 | 1998-06-12 | 6185706 | 09097081 |
| Isolation trench in semiconductor substrate with nitrogen-containing barrier region, and process for forming same | United States of America | Granted | 2000-12-05 | 1998-07-22 | 6156620 | 09121283 |
| | Japan | Lapsed | 2012-02-24 | 1998-03-18 | 4932980 | 1998068296 |
| Process For Forming MOS Device In Integrated Circuit Structure Using Cobalt Silicide Contacts As Implantation Media | Korea, Republic of (KR) | Lapsed | 2005-12-09 | 1998-06-30 | 537034 | 1019980025571 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
| | | | | | | |

| Method For Making Enhanced Performance Field Effect Devices | United States of America | Granted | 2000-11-14 | 1999-08-30 | 6146913 | 09385258 |
|--|--------------------------|---------|------------|------------|-----------|----------|
| Integration Of Low K Dielectric Material In Semiconductor Circuit Structures | United States of America | Granted | 2003-12-02 | 1999-12-17 | 6657302 | 09464811 |
| Method Of Making A Capacitor | United States of America | Granted | 2002-03-19 | 1999-02-16 | 6358790 | 09250501 |
| Integrated Circuit Capacitor Including Anchored Plugs | United States of America | Granted | 2001-09-18 | 1999-07-30 | 6291848 | 09364767 |
| Multiple Purpose Reticle Layout For Selectively Printing Of Test Circuits | United States of America | Lapsed | 2005-05-17 | 2002-08-15 | 6893806 | 10219951 |
| Predictive Applications For Devices With Thin Dielectric Regions | United States of America | Granted | 2007-06-12 | 2004-08-30 | 7230812 | 10930544 |
| Method Of Planarizing A Surface Of An Integrated Circuit | United States of America | Granted | 2001-08-28 | 1999-04-23 | 6280644 | 09298792 |
| High Quality Oxide For Use In Integrated Circuits | United States of America | Granted | 2002-12-10 | 2000-06-20 | 6492712 | 09597077 |
| System And Method For Removal Of Material | United States of America | Lapsed | 2003-07-08 | 2000-11-14 | 6588437 | 09712732 |
| Phase Shift Gate Lithography For High-Speed Low Voltage DSPs | United States of America | Expired | | 1999-11-03 | | 60163230 |
| Structures | United States of America | Expired | | 1999-01-12 | | 60115604 |
| Integration Of Low Dielectric Material In Semiconductor Circuit | | | | | | |
| Article Comprising Fluorinated Diamond-Like Carbon And Method For Fabricating Article | United States of America | Expired | | 1998-03-12 | | 60077720 |
| Process For Fabricating A Lithographic Mask | United States of America | Expired | | 1998-04-29 | | 60083547 |
| Damascene Capacitors For Integrated Circuits | United States of America | Expired | | 1999-01-12 | | 60115520 |
| Process For Device Fabrication | United States of America | Expired | | 1997-07-14 | | 60052440 |
| Application | United States of America | Expired | | 1999-01-13 | | 60115842 |
| Aluminum Barrier Layer For High-IC Dielectric In Capacitors/Gate | | | | | | |
| Method Of Making A Capacitor | United States of America | Expired | | 1999-01-13 | | 60115762 |
| High Quality Oxide For Use In Integrated Circuits | United States of America | Expired | | 1999-06-24 | | 60140909 |
| Substrate profile analysis | United States of America | Lapsed | 2006-05-02 | 2004-06-14 | 7039556 | 10867003 |
| Method to monitor pad wear in CMP processing | United States of America | Granted | 2007-04-03 | 2004-06-29 | 7198546 | 10879629 |
| Method for implanting ions in a semiconductor | United States of America | Granted | 2006-12-12 | 2002-08-23 | 7148131 | 10226884 |
| Wafer edge structure measurement method | United States of America | Granted | 2007-12-25 | 2004-08-24 | 7312880 | 10925497 |
| Diamond metal-filled patterns achieving low parasitic coupling capacitance | United States of America | Granted | 2005-03-15 | 2002-12-19 | 6867127 | 10327283 |
| Electroplating | United States of America | Granted | 2010-01-05 | 2005-03-10 | 7641776 | 11078179 |
| System and Method for Increasing Yield from Semiconductor Wafer | | | | | | |
| Method of Design Based Process Control Optimization | United States of America | Lapsed | 2009-08-04 | 2005-11-02 | 7571397 | 11265040 |
| Method and apparatus for diverting void diffusion in integrated circuit conductors | United States of America | Granted | 2008-10-14 | 2005-12-29 | 7436040 | 11323398 |
| layer prior to planarizing | United States of America | Granted | 2002-07-09 | 2000-10-31 | 6417093 | 09703745 |
| Process for planarization of metal-filled trenches of integrated circuit structures by forming a layer of planarizable material over the metal | | | | | | |
| Tier territories and the second secon | Country | Status | Grantbate | недрате | Patentino | Appino |
| Party. | | | | | | |

| Method Of Global Planarization In Fabricating Integrated Circuit Devices | United States of America | Expired | 1999-03-23 | 1995-11-07 | 5885900 | 08554501 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Integrated Circuit Conductors That Avoid Current Crowding | United States of America | Granted | 1999-10-19 | 1997-11-18 | 5969421 | 08972904 |
| A Process For Fabricating A Device With Shallow Junctions | United States of America | Granted | 2000-10-24 | 1998-02-12 | 6136673 | 09023220 |
| Method Of Making An Organic Thin Film Transistor | United States of America | Expired | 2000-08-22 | 1996-12-20 | 6107117 | 08770535 |
| Silicon Germanium Heterostructure Bipolar Transistor With Indium Doped Base | United States of America | Granted | 2000-07-11 | 1998-07-31 | 6087683 | 09127373 |
| Method For The Fabrication Of Contacts In An Integrated Circuit Device | United States of America | Lapsed | 2006-01-03 | 1998-06-05 | 6982226 | 09092158 |
| A Method For Forming Dual-Polysilicon Structures Using A Built-In Stop Layer | United States of America | Granted | 2002-04-02 | 1998-08-26 | 6365469 | 09140276 |
| Layered Silicon Nitride Deposition Process | United States of America | Granted | 1999-11-09 | 1997-11-24 | 5981403 | 08977319 |
| Membrane Mask For Projection Lithography | United States of America | Granted | 1999-11-16 | 1998-04-08 | 5985493 | 09057420 |
| Integrated Circuit Fabrication | United States of America | Expired | 1998-12-08 | 1997-08-26 | 5846871 | 08918394 |
| A Lithographic Process Having Sub-Wavelength Resolution | United States of America | Granted | 2001-04-17 | 1999-04-16 | 6218057 | 09293103 |
| Process For Synthesizing A Palladium Replenisher For Electroplating Baths | United States of America | Granted | 2002-02-12 | 1999-06-01 | 6346222 | 09323607 |
| Method and apparatus for integrating Six Sigma methodology into inspection receiving process of outsourced subassemblies, parts, and materials: acceptance, rejection, trending, tracking and closed loop corrective action | United States of America | Granted | 2007-02-20 | 2003-08-04 | 7181353 | 10634416 |
| Process For The Fabrication Of Dual Gate Structures For CMOS Devices | United States of America | Granted | 2003-05-20 | 1999-02-26 | 6566181 | 09259028 |
| Method For Making Integrated Circuit Capacitor Including Anchored Plugs | United States of America | Granted | 2000-08-15 | 1999-07-30 | 6103586 | 09364025 |
| Method Of Etching Self-Aligned Vias To Metal Using A Silicon Nitride Spacer | United States of America | Granted | 2001-09-11 | 1999-12-28 | 6287952 | 09473876 |
| Tactile Sensor Comprising Nanowires And Method For Making The Same | United States of America | Granted | 2001-09-11 | 1999-09-24 | 6286226 | 09405641 |
| Measurement Technique For Ultra-Thin Oxides | United States of America | Lapsed | 2004-05-04 | 2001-01-04 | 6731386 | 09754611 |
| A Method of Testing an Integrated Circuit | United States of America | Granted | 2003-09-16 | 2000-06-27 | 6621280 | 09603717 |
| Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And A Capacitor | United States of America | Granted | 2004-07-13 | 2000-06-16 | 6762087 | 09596382 |
| Nonintrusive wafer marking | United States of America | Granted | 2004-09-28 | 2003-10-07 | 6797585 | 10680047 |
| Method and Apparatus for Deposition of Porous Silica Dielectrics | United States of America | Abandoned | | 2001-05-23 | | 09863979 |
| An Inductor Or Low Loss Interconnect And A Method Of Manufacturing An Inductor Or Low Loss Interconnect In An Integrated Circuit | United States of America | Granted | 2002-05-28 | 1999-11-01 | 6395611 | 09432725 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
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| Method For Processing Silicon Workpieces Using Hybrid Optical Thermometer System | Korea, Republic of (KR) | Lapsed | 2007-04-11 | 2000-04-04 | 708585 | 20000017524 |
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| (KR) Process For Fabricating Vertical Transistors | Korea, Republic of (KR) | Lapsed | 2006-04-13 | 1999-08-27 | 572647 | 1019990035816 |
| Method For Producing Piezoelectric Films With Rotating Magnetron (KR) Sputtering System | Korea, Republic of (KR) | Lapsed | 2008-09-18 | 2001-02-09 | 10-0860182 | 20010006412 |
| (KR) Method For Producing Devices Having Piezoelectric Films | Korea, Republic of (KR) | Lapsed | 2008-09-17 | 2001-02-12 | 859674 | 1020010006759 |
| | Korea, Republic of (KR) | Lapsed | 2007-10-30 | 2001-08-31 | 773256 | 1020010053297 |
| Electrostatic Discharge Protection Device With Monolithically Formed (KR) Resistor-Capacitor Portion | Korea, Republic of (KR) | Lapsed | 2008-05-07 | 2001-07-16 | 829404 | 1020010042929 |
| | Korea, Republic of (KR) | Lapsed | 2007-03-30 | 2000-11-30 | 704132 | 1020000071927 |
| An integrated circuit device and a process for forming the same | Taiwan | Granted | 2011-07-01 | 2004-03-29 | 1344685 | 093108543 |
| Method For Separating A Semiconductor Wafer Into Individual Semiconductor Dies Using An Implanted Inpurity | Taiwan | Granted | 2012-11-11 | 2008-05-16 | 1376768 | 097118239 |
| Method And Apparatus For Manufacturing Multiple Circuit Patterns Using A Multiple Project Mask | Taiwan | Granted | 2010-11-01 | 2004-04-14 | 1332677 | 093110399 |
| Method Of Making An Organic Thin Film Transistor | Taiwan | Lapsed | 2000-06-21 | 1997-12-10 | NI-116286 | 86118596 |
| A Method For Fabricating A Merged Integrated Circuit Device | Taiwan | Lapsed | 2002-09-11 | 2000-02-01 | NI-162628 | 89101735 |
| Device And Method For Polishing A Semiconductor Substrate | Taiwan | Granted | 2003-07-21 | 1999-04-01 | NI-181704 | 88105178 |
| Vertical Replacement Gate (VRG) MOSFET With A Conductive Layer Adjacent A Source/Drain Region And Method Of Manufacture Therefor | Taiwan | Lapsed | 2002-12-11 | 2001-03-20 | NI-161626 | 90106474 |
| A Method of Testing an Integrated Circuit | Taiwan | Lapsed | 2003-08-01 | 2001-06-20 | NI-182552 | 90114970 |
| Methods of Fabricating A Metal-Oxide-Metal Capacitor And Associated Apparatus | Taiwan | Granted | 2003-03-14 | 2001-08-28 | NI-166024 | 90121234 |
| nerica Method of screening defects using low voltage IDDQ measurement | United States of America | Lapsed | 2005-10-11 | 2003-06-23 | 6954705 | 10602357 |
| Method For Improved Encapsulation Of Thick Metal Features In Integrated Circuit Fabrication | United States of America | Granted | 2002-10-29 | 2000-01-27 | 6472307 | 09491644 |
| nerica Method and Arrangement for Characterizing Micro-Size Patterns | United States of America | Expired | 1997-03-04 | 1995-02-15 | 5607800 | 08388934 |
| Dose Modification Proximity Effect Compensation (PEC) Technique For erica Electron Beam Lithography | United States of America | Expired | 1998-04-07 | 1996-06-07 | 5736281 | 08660632 |
| nerica Method Of Mechanical Polishing | United States of America | Expired | 2000-08-29 | 1997-09-04 | 6110831 | 08923316 |
| Apparatus For Controlling A Charged Particle Beam And A Lithographic Process In Which The Apparatus Is Used | United States of America | Expired | 1997-09-02 | 1995-10-20 | 5663568 | 08546078 |
| Masks With Low Stress Multilayer Films And A Process For Controlling nerica The Stress Of Multilayer Films | United States of America | Expired | 1996-03-19 | 1994-10-11 | 5500312 | 08321362 |
| nerica Method of Preparing Silicon Wafers | United States of America | Expired | 1996-06-25 | 1994-07-26 | 5529051 | 08280429 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| | Germany (Federal Republic of) | Lapsed | 2012-07-04 | 1999-03-29 | 69944291.5 | 993024413 |
|---|-------------------------------|---------|------------|------------|------------|---------------|
| Power A | | Granted | 2009-10-14 | 2000-11-06 | 60043148.7 | 003098035 |
| Process for Forming Device Comprising Micromagnetic Components for | Germany (Federal Republic | | | | | |
| Article Comprising A Variable Inductor | of) | Granted | 2009-08-26 | 2000-07-03 | 60042804.4 | 003055712 |
| _ | Germany (Federal Renublic | 5 | | | | |
| Reticle overlay correction | United States of America | Lapsed | 2006-03-21 | 2002-09-06 | 7016041 | 10236226 |
| Anti-corrosion system | United States of America | Granted | 2003-01-14 | 2000-05-24 | 6506684 | 09577912 |
| Contamination distribution apparatus and method | United States of America | Lapsed | 2005-11-29 | 2002-12-09 | 6969621 | 10315480 |
| Method For Making A Semiconductor Device | Japan | Lapsed | 2011-04-08 | 2001-01-17 | 4718021 | 2001009397 |
| Apparatus | Japan | Granted | 2012-09-21 | 2001-08-31 | 5090598 | 2001262994 |
| Methods of Fabricating A Metal-Oxide-Metal Capacitor And Associated | | | | | | |
| Fabricating High-Q RF Component | Japan | Granted | 2005-12-22 | 2000-03-01 | 3753915 | 2000056110 |
| Making Such Articles | Japan | Expired | 2005-05-13 | 1997-02-03 | 3677137 | 09020253 |
| Articles Comprising Magnetically Soft Thin Films And Methods For | | | | | | |
| Thin Film Tantalum Oxide Capacitors And Resulting Product | Japan | Lapsed | 2006-02-10 | 1998-02-25 | 3768671 | 10043609 |
| Mold For Non-Photolithographic Fabrication Of Microstructures | Japan | Lapsed | 2004-03-26 | 1999-03-26 | 3538335 | 11083888 |
| Fabricating Article | Japan | Granted | 2002-12-06 | 1999-03-12 | 3378210 | 11065741 |
| Article Comprising Fluorinated Diamond-Like Carbon And Method For | | | | | | |
| Process For Fabricating Bipolar And BICMOS Devices | Japan | Lapsed | 2002-07-12 | 1999-03-12 | 3328600 | 11065740 |
| A Method of Testing an Integrated Circuit | Korea, Republic of (KR) | Lapsed | 2010-09-15 | 2001-06-27 | 10-983457 | 1020010036899 |
| Polishing Composition for CMP Operations | of) | Expired | 2002-10-16 | 1996-12-19 | 69624326.1 | 963093182 |
| | Germany (Federal Republic | | | | | |
| CMOS Vertical Replacement Gate (VRG) Transistors | Korea, Republic of (KR) | Lapsed | 2009-06-23 | 2002-12-26 | 10-905210 | 1020020084019 |
| Lens Array For Electron Beam Lithography Tool | Korea, Republic of (KR) | Lapsed | 2007-09-04 | 2000-10-06 | 757215 | 1020000058829 |
| A Method Of Manufacturing An Integrated Circuit Package | Korea, Republic of (KR) | Lapsed | 2008-02-05 | 2001-07-20 | 803643 | 1020010043828 |
| Formed | Korea, Republic of (KR) | Lapsed | 2005-01-21 | 1997-04-04 | 469221 | 9712486 |
| Process For Device Eabrication In Which A Thin Laver Of Cohalt Silicide Is | Rolea, Republic of (NIV) | гарзеп | 00-00-2002 | CT-0T-066T | 323133 | 9040100 |
| | Korea Republic of (KR) | 2002 | שה כה בחהב | 1000 10 15 | 220120 | |
| Method For The Fabrication Of Contacts In An Integrated Circuit Device | Korea, Republic of (KR) | Lapsed | 2003-02-10 | 1999-06-04 | 373193 | 1019990020699 |
| Which Has Been Previously Inspected | Korea, Republic of (KR) | Lapsed | 2001-04-16 | 1998-12-09 | 294359 | 9853846 |
| Lithographic Process For Device Fabrication Using A Multilayer Mask | | | | | | |
| Substrate | Korea, Republic of (KR) | Lapsed | 2001-12-26 | 1998-11-04 | 320163 | 9847146 |
| Method For Using A Hardmask To Form An Opening In A Semiconductor | | | | | | |
| A Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And An Integrated Circuit | Korea, Republic of (KR) | Lapsed | 2006-08-16 | 2000-08-30 | 614782 | 1020000050713 |
| A Droppes For Manufacturing An Integrated Circuit Including A Dual | - | 1 | 3 | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNn | Annun |

| Die attach back grinding | United States of America | Lapsed | 2003-09-23 | 2001-12-05 | 6624048 | 10005097 |
|--|-------------------------------|-----------|------------|------------|------------------|---------------|
| Low temperature process for forming a low dielectric constant fluorine and carbon-containing silicon oxide dielectric-material characterized by improved resistance to oxidation and good gap-filling capabilities | United States of America | Granted | 2002-04-02 | 2000-06-07 | 6365528 | 09590310 |
| Semiconductor Test Device With Heating Circuit | United States of America | Lapsed | 2010-09-28 | 2007-02-12 | 7804291 | 11673714 |
| Semiconductor Devices | United States of America | Lapsed | 2009-06-16 | 2006-09-12 | 7547560 | 11519614 |
| Process For Fabricating A Device Using Nitrogen Implantation Into Silicide Layer Layer And Mathod For Bonairing Willow Defects In | United States of America | Expired | 1998-12-22 | 1997-05-29 | 5851922 | 08865548 |
| A Spiral Inductor Formed In A Semiconductor Substrate And A Method For Forming The Inductor | China | Lapsed | 2010-07-21 | 2004-08-04 | ZL200810210288.X | 200810210288X |
| Method For Making A Semiconductor Device | Japan | Abandoned | | 2007-09-13 | | 2007237928 |
| | United States of America | Lapsed | 2005-08-16 | 2002-05-13 | 6930006 | 10144511 |
| An In\(miSitu Electroplated Oxide Passivating Film For Corrosion Inhibition | United States of America | Lapsed | 2003-02-25 | 2001-09-17 | 6524957 | 09953706 |
| Process for inhibiting edge peeling of coating on semiconductor substrate during formation of integrated circuit structure thereon | United States of America | Granted | 2004-07-27 | 2001-11-28 | 6767692 | 09997071 |
| Arrangement for measuring pressure on a semiconductor wafer and an associated method for fabricating a semiconductor wafer | United States of America | Granted | 2004-08-03 | 2001-09-21 | 6770505 | 09960441 |
| High frequency electrochemical deposition | United States of America | Granted | 2004-05-18 | 2001-09-28 | 6736953 | 09966651 |
| Deep submicron silicide blocking | United States of America | Lapsed | 2003-07-01 | 2001-10-16 | 6586332 | 09981154 |
| Method For Producing Piezoelectric Films With Rotating Magnetron Sputtering System | Germany (Federal Republic of) | Granted | 2011-05-11 | 2001-01-29 | 60144587.2 | 013007489 |
| Article Comprising A Relatively Temperature-Insensitive Ta-Oxide Based Capacitive Element | Germany (Federal Republic of) | Expired | 2005-08-24 | 1997-10-14 | 69734047.3 | 973081268 |
| | United States of America | Granted | 2001-11-20 | 2000-09-26 | 6319836 | 09669979 |
| Electronic Apparatus | of) | Granted | 2001-11-28 | 1998-01-27 | 69802659.4 | 983005505 |
| | Germany (Federal Republic | | | | | |
| Semiconductor Device Having Aluminum Contacts Or Vias And Method Of Manufacture Therefor | Germany (Federal Republic of) | Lapsed | 2005-11-09 | 1998-03-11 | 69832226.6 | 983018037 |
| GaAs-Based MOSFET, And Method Of Making Same | Germany (Federal Republic of) | Lapsed | 1999-10-13 | 1998-02-17 | 69800026.9 | 983011545 |
| Process For Fabricating Vertical Transistors | Germany (Federal Republic of) | Lapsed | 2003-07-02 | 1999-08-17 | 69909205.1 | 993064468 |
| Thin Film Transistors | Germany (Federal Republic of) | Granted | 2008-08-20 | 2000-11-20 | 60039956.7 | 003103058 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Process for forming re-entrant geometry for gate electrode of integrated circuit structure | United States of America | Expired | 2000-05-09 | 1996-07-31 | 6060375 | 08690577 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Rapid Thermal Processing Using A Narrowband Infrared Source And Feedback | Japan | Expired | 2007-11-16 | 1997-07-11 | 4041187 | 09186793 |
| Method for fabricating a field effect transistor using microtrenches to control hot electron effects | United States of America | Expired | 1998-04-07 | 1996-06-07 | 5736418 | 08659860 |
| Plasma clean with hydrogen gas | United States of America | Expired | 1997-08-26 | 1996-03-14 | 5660682 | 08615437 |
| Modified carrier films to produce more uniformly polished substrate surfaces | United States of America | Expired | 2000-06-13 | 1997-10-30 | 6074288 | 08961382 |
| Apparatus for polishing a substrate at radially varying polish rates | United States of America | Expired | 1998-10-06 | 1997-07-17 | 5816900 | 08895659 |
| Methods and apparatus for electrical marking of integrated circuits to record manufacturing test results | United States of America | Expired | 1999-12-07 | 1997-07-25 | 5998853 | 08900845 |
| Conditioning CMP polishing pad using a high pressure fluid | United States of America | Expired | 1999-09-28 | 1997-10-30 | 5957757 | 08960969 |
| Testing ESD protection schemes in semiconductor integrated circuits | United States of America | Granted | 1999-11-02 | 1997-11-18 | 5978197 | 08972231 |
| Probe points and markers for critical paths and integrated circuits | United States of America | Granted | 2000-08-01 | 1997-12-08 | 6097884 | 08986537 |
| Process monitor circuitry for integrated circuits | United States of America | Granted | 2000-09-26 | 1998-01-26 | 6124143 | 09013510 |
| Liquid level sensor for buffered hydrofluoric acid | United States of America | Granted | 2000-03-07 | 1999-05-28 | 6032529 | 09322191 |
| Process for treating damaged surfaces of low dielectric constant organo silicon oxide insulation material to inhibit moisture absorption | United States of America | Granted | 2000-02-22 | 1999-03-29 | 6028015 | 09281514 |
| Image sensor array with picture element sensor testability | United States of America | Expired | 1997-08-05 | 1995-06-30 | 5654537 | 08496861 |
| Reduction of silicon defect induced failures as a result of implants in CMOS and other integrated circuits | United States of America | Granted | 2000-05-30 | 1998-09-30 | 6069048 | 09163623 |
| Use of MEV Implantation to Form a Vertically Modulated n+ Buried Layer in an NPN Bipolar Transistor | Taiwan | Granted | 1999-11-11 | 1998-02-17 | 109370 | 87102155 |
| Apparatus and method of planarizing a semiconductor wafer that includes a first reflective substance and a second reflective substance | United States of America | Granted | 2001-11-13 | 1998-12-17 | 6316276 | 09213803 |
| Method for forming an ion implanted electrostatic chuck | United States of America | Granted | 2000-09-05 | 1998-12-03 | 6115232 | 09204815 |
| Depletion free polysilicon gate electrodes | United States of America | Granted | 2000-07-18 | 1999-11-05 | 6090651 | 09434340 |
| Method and apparatus for maintaining test data during fabrication of a semiconductor wafer | United States of America | Granted | 2001-08-14 | 1999-12-23 | 6274395 | 09471842 |
| System to reduce particulate contamination | United States of America | Granted | 2002-03-12 | 2000-05-30 | 6355577 | 09580106 |
| Polishing pad surface for improved process control | United States of America | Expired | 2001-01-02 | 1997-08-25 | 6168508 | 08918293 |
| Automated inspection system for residual metal after chemical-mechanical polishing | United States of America | Expired | 2000-08-22 | 1997-06-04 | 6108093 | 08869278 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Process to provide enhanced resistance to cracking and to further reduce the dielectric constant of a low dielectric constant dielectric film of an integrated circuit structure by implantation with hydrogen ions | United States of America | Granted | 2002-02-12 | 2000-06-27 | 6346488 | 09605382 |
|---|----------------------------------|---------|------------|------------|------------|---------------|
| Method of forming a high electromigration resistant metallization system | United States of America | Expired | 1998-07-07 | 1995-12-27 | 5776831 | 08578118 |
| Wafer holder for backside viewing, frontside probing on automated wafer probe stations | United States of America | Granted | 2004-06-08 | 2001-06-21 | 6747464 | 09888302 |
| Utility wafer for chemical-mechanical planarization | United States of America | Expired | 1999-04-06 | 1996-04-15 | 5890951 | 08632550 |
| CMOS Vertical Replacement Gate (VRG) Transistors | Japan | Lapsed | 2014-07-18 | 2013-01-11 | 5579280 | 20133034 |
| Method for improvement of TiN CVD film quality | United States of America | Expired | 1999-09-21 | 1995-12-27 | 5956613 | 08579383 |
| Multilevel metallization structure for integrated circuit I/O lines for increased current capacity and ESD protection | United States of America | Expired | 1998-08-04 | 1996-04-02 | 5789783 | 08626776 |
| Method To Improve Metal Defects In Semiconductor Device Fabrication | Korea, Republic of (KR) | Granted | 2014-01-08 | 2013-09-23 | 10-1351293 | 1020130112914 |
| Method of making a sloped sidewall via for integrated circuit structure to suppress via poisoning | United States of America | Granted | 2003-05-06 | 2001-05-30 | 6559048 | 09870851 |
| Method For Separating A Semiconductor Wafer Into Individual Semiconductor Dies Using An Implanted Inpurity | Japan | Lapsed | 2014-07-18 | 2007-05-17 | 5580439 | 201313971 |
| Process for forming a low k carbon-doped silicon oxide dielectric material on an integrated circuit structure | United States of America | Granted | 2003-06-24 | 2001-05-31 | 6583026 | 09872058 |
| Keyed end effector for CMP pad conditioner | United States of America | Expired | 1997-09-16 | 1995-06-07 | 5667433 | 08481799 |
| High surface area trenches for an integrated ciruit device | United States of America | Expired | 1997-09-02 | 1995-09-21 | 5662768 | 08531659 |
| Guard rings to compensate for side lobe ringing in attenuated phase shift reticles | United States of America | Expired | 1998-08-18 | 1996-03-08 | 5795682 | 08613161 |
| Plasma Cleaning Process for Openings Formed in One or More Low Dielectric Constant Insulation Layers Over Copper Metallization In Integrated Circuit Structures | Germany (Federal Republic of) | Lapsed | 2004-08-11 | 2000-03-29 | 60012807.5 | 003025905 |
| In situ liner barrier | United States of America | Granted | 2004-07-27 | 2001-04-27 | 6767832 | 09844352 |
| Input-output (I/O) structure with capacitively triggered thyristor for electrostatic discharge (ESD) protection | United States of America | Expired | 1997-10-28 | 1995-06-07 | 5682047 | 08484003 |
| Microelectronic integrated circuit including hexagonal semiconductor "AND" gate | United States of America | Expired | 1997-08-12 | 1995-03-01 | 5656850 | 08396542 |
| Process for low energy implantation of semiconductor substrate using channeling to form retrograde wells | United States of America | Expired | 1999-05-18 | 1996-04-12 | 5904551 | 08631360 |
| Apparatus and method for measuring quiescent current utilizing timeset switching | United States of America | Expired | 1997-09-23 | 1995-10-20 | 5670892 | 08545880 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Novel Method Of Making EDRAM Capacitor | United States of America | Expired | | 1999-01-13 | | 60115781 |
|---|--------------------------|-------------|------------|------------|-------------------|---------------|
| Failure Analysis Vehicle for Yield Enhancement with Self Test at Speed Burning Capability for Reliability Testing | China | Granted | 2009-10-07 | 2005-08-18 | ZL200510092707.0 | 2005100927070 |
| Bipolar Transistors having Controllable Temperature Coefficient of Current Gain | United States of America | Lapsed | 2009-01-27 | 2005-03-11 | 7482642 | 11078830 |
| Stacked High-K Dielectric Capacitor For Dual Damascene Structure | United States of America | Expired | | 1999-01-12 | | 60115526 |
| Aluminum Pad Power Bus In A Copper Technology | United States of America | Expired | | 2003-04-10 | | 60462504 |
| Low Temperature Tungsten Deposition | United States of America | Expired | | 1999-05-24 | | 60135564 |
| Wafer level dynamic burn-in | United States of America | Granted | 2004-03-23 | 2001-07-30 | 6710616 | 09918183 |
| For Forming The Inductor | China | Lapsed | 2011-12-28 | 2004-08-04 | ZL 201010115825.X | 201010115825X |
| Multi-surfaced plate-to-plate capacitor and method of forming same | United States of America | Granted | 2008-02-05 | 2005-11-02 | 7327011 | 11266133 |
| Superconductor wires for back end interconnects | United States of America | Granted | 2008-03-11 | 2005-03-04 | 7341978 | 11072158 |
| die from a process monitor derating factor | United States of America | Lapsed | 2006-06-27 | 2004-09-29 | 7069178 | 10955168 |
| Method of predicting quiescent current variation of an integrated circuit | | | | | | |
| Process And Apparatus For Simultaneous Light And Radical Surface Treatment Of Integrated Circuit Structure | United States of America | Lapsed | 2009-06-30 | 2005-01-31 | 7553772 | 11046949 |
| Reduced dry etching lag | United States of America | Granted | 2006-08-22 | 2005-03-02 | 7094687 | 11071903 |
| Devices Utilizing Copper Technology Interconnect Structures | Japan | Abandoned | | 2011-10-27 | | 2011236296 |
| Aluminum Pad Power Bus And Signal Routing For Integrated Circuit | | | | | | |
| Low K Dielectric Composite Layer for Integrated Circuit Structure Which Provides Void-Free Low K Dielectric Material Between Metal Lines While Mitigating Via Poisoning | Japan | Lapsed | 2011-04-28 | 2000-10-19 | 4731670 | 2000319053 |
| Testing with high speed pulse generator | United States of America | Granted | 2007-05-08 | 2005-07-19 | 7216279 | 11184621 |
| A Spiral Inductor Formed In A Semiconductor Substrate And A Method For Forming The Inductor | Taiwan | Granted | 2013-12-01 | 2004-06-29 | 1418017 | 102102447 |
| Self-Timed Reliability and Yield Vehicle with Gated Data and Clock | Taiwan | Granted | 2012-08-01 | 2005-06-15 | 1369504 | 094119790 |
| Self-Timed Reliability and Yield Vehicle with Gated Data and Clock | China | Granted | 2010-06-23 | 2005-07-25 | ZL200510088210.1 | 2005100882101 |
| I ungsten local interconnect for silicon integrated circuit structures, and method of making same | United States of America | Granted | 2001-12-11 | 1998-12-16 | 6329720 | 09212450 |
| | European Patent | Application | | 2000-01-06 | | 003000437 |
| Device frequency measurement system | United States of America | Granted | 2003-04-29 | 2000-11-29 | 6556021 | 09725631 |
| Failure Analysis Vehicle for Yield Enhancement with Self Test at Speed Burnin Capability for Reliability Testing | Taiwan | Granted | 2012-05-11 | 2005-07-21 | 1364081 | 94124738 |
| Low K Dielectric Composite Layer for Integrated Circuit Structure Which Provides Void-Free Low K Dielectric Material Between Metal Lines While Mitigating Via Poisoning | European Patent | Lapsed | | 2000-10-18 | | 001226844 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Yield Improvement Via Automatic Analysis Of Wafer Processing Order | United States of America | Expired | | 1998-08-13 | | 60096407 |
|--|--------------------------|-----------|------------|--------------------|-----------|---------------|
| Method Of Planarizing A Surface Of An Integrated Circuit | United States of America | Expired | | 1998-06-05 | | 60088157 |
| Devices | United States of America | Lapsed | 2010-07-27 | 2005-07-25 | 7763908 | 11189217 |
| Design Of Silicon-Controlled Rectifier By Considering Electrostatic Discharge Robustness In Human-Body Model And Charged-Device Model | | | | | | |
| A Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And An Integrated Circuit | Japan | Granted | | 5334616 2009-02-16 | 5334616 | 2009032389 |
| A Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And An Integrated Circuit | Japan | Abandoned | | 2009-02-23 | | 2009038940 |
| Process For Device Fabrication Using A Variable Transmission Aperture | United States of America | Granted | 2000-01-18 | 1998-11-12 | 6015644 | 09190351 |
| Tapered Plug For EDRAM/Capacitor Application | United States of America | Expired | | 1999-01-13 | | 60115785 |
| Vertical Replacement-Gate Junction Field-Effect Transistor | Korea, Republic of (KR) | Granted | 2009-11-24 | 2009-07-21 | 10-929335 | 1020090066235 |
| Process For Fabricating A Lithographic Mask | United States of America | Granted | 2000-04-18 | 1998-07-23 | 6051346 | 09121266 |
| Process For Forming A Plasma Nitride Film Suitable For Gate Dielectric Application In Sub\(mi0.25 \\/*mm Technologies | United States of America | Granted | 2001-10-30 | 1999-06-16 | 6309932 | 09334491 |
| Architecture for Circuit Connection of a Vertical Transistor | Japan | Lapsed | 2014-02-21 | 2009-10-08 | 5479839 | 2009234206 |
| Impact Of Plasma-Charging Damage On Yield And Reliability In Deep Submicron CMOS VLSI Circuits | United States of America | Expired | | 1999-06-28 | | 60141348 |
| Fully\(milsolated Thin\(miFilm Trench Capacitor | United States of America | Granted | 2001-07-10 | 1999-02-03 | 6259149 | 09243047 |
| A Multi-Layer Inductor Formed In A Semicondutor Substrate | United States of America | Granted | 2003-10-28 | 2001-10-05 | 6639298 | 09972482 |
| Method Of Determining The Impact Of Plasma-Charging Damage On Yield And Reliability In Submicron Integrated Circuits | United States of America | Granted | 2002-04-02 | 2000-04-30 | 6365426 | 09560935 |
| Novel Method Of Coil Preparation For Ionized Metal Plasma Processes | United States of America | Expired | | 2000-04-14 | | 60197283 |
| Control Of Hot Carrier Degradation In LDMOS Devices By A Dummy Gate Field Plate | United States of America | Expired | | 2003-11-14 | | 60520265 |
| Fully shielded capacitor cell structure | United States of America | Granted | 2006-12-26 | 2004-09-20 | 7154734 | 10945177 |
| Full Via First Integration Method Of Manufacture | United States of America | Expired | | 2001-06-28 | | 60301295 |
| Electron Beam Imaging Apparatus | United States of America | Expired | | 1999-10-07 | | 60158268 |
| CMOS With Metal Gates By Work Function Engineering | United States of America | Expired | | 1999-12-03 | | 60168911 |
| System And Method For Removal Of Material | United States of America | Expired | | 1999-11-15 | | 60165542 |
| Wafer Edge Expose Alignment Method | United States of America | Lapsed | 2010-09-21 | 2004-09-20 | 7799166 | 10944996 |
| Method and apparatus for implementing a co-axial wire in a semiconductor chip | United States of America | Lapsed | 2006-03-21 | 2004-08-26 | 7015569 | 10927985 |
| A Process For Device Fabrication Using A Variable Transmission Aperture | United States of America | Expired | | 1998-02-20 | | 60075293 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 09365059 | | | | | | Field Emitting Device Comprising Metallized Nanostructures And Method |
|------------|---------|--------------------------|------------|-----------------|---|--|
| | 6504292 | 1999-07-30 | 2003-01-07 | Granted | United States of America | For Making The Same |
| 09943196 | 7601643 | 2001-08-30 | 2009-10-13 | Lapsed | United States of America | Use of Non Aqueous Solvents in Low k CMP |
| 60098431 | | 1998-08-31 | | | United States of America | Method For Making Enhanced Performance Field Effect Devices |
| 60174549 | | 2000-01-05 | | Expired | United States of America | An Integrated Circuit And A Method Of Making An Integrated Circuit |
| 60524341 | | 2003-11-21 | | Expired | United States of America | Method Of Determining The Reliability Of Semiconductor Devices Having Thin Gate Oxides |
| 10969745 | 7171638 | 2004-10-20 | 2007-01-30 | Granted | United States of America | Methods of screening ASIC defects using independent component analysis of quiescent current measurements |
| 09755878 | 7638380 | 2001-01-04 | 2009-12-29 | | United States of America | |
| | | 200 | | | Kasaa Baarklia af (KB) | Method For Separating A Semiconductor Wafer Into Individual |
| 09842214 | 6969472 | 2001-04-25 | 2005-11-29 | Lapsed | United States of America | Method of fabricating sub-micron hemispherical and hemicylidrical structures from non-spherically shaped templates |
| 09591626 | 6420714 | 2000-06-09 | 2002-07-16 | Granted | United States of America | Electron Beam Imaging Apparatus |
| 2010508351 | | 71-50-2002 | | Abandoned | ueder | Method For Separating A Semiconductor Wafer Into Individual Semiconductor Dies Using An Implanted Inpurity |
| 10505198 | 7342225 | 2005-03-02 | 2008-03-11 | Granted | United States of America | Crystallographic Metrology And Process Control |
| 09364603 | 6249016 | 1999-07-30 | 2001-06-19 | Granted | United States of America | Integrated Circuit Capacitor Including Tapered Plug |
| 60128937 | | 1999-04-13 | | Expired | United States of America | A Method For Matching Thin Film Thickness Measurement Tools |
| 60144547 | | 1999-07-15 | | Expired | United States of America | Field Emitting Device Comprising Metalized Nanostructures And Method For Making The Same |
| 60143691 | | 1999-07-14 | | Expired | United States of America | Buried In Glass Silicon Tantalum Integrated Circuit (BIG STIC) |
| 60106945 | | 1998-11-04 1999-01-14 | | Expired Expired | United States of America United States of America | An Inductor Or Low Loss Interconnect In An Integrated Circuit A Plasma Nitride Process Suitable For Gate Dielectric Application In Sub\\mi0.25 \\{*mm Technologies |
| 08943585 | 5904523 | 1997-10-03 | 1999-05-18 | | United States of America | Process For Device Fabrication In Which A Layer Of Oxynitride Is Formed At Low Temperatures |
| 60028049 | | 1996-10-03 | | Expired | United States of America | A Process For Device Fabrication |
| 09205840 | 6312766 | 1998-12-04 | 2001-11-06 | _ | United States of America | Article Comprising Fluorinated Diamond-Like Carbon And Method For Fabricating Article |
| 09211481 | 6336086 | 1998-12-14 | 2002-01-01 | Granted | United States of America | Method And System For Analyzing Wafer Processing Order |
| 60116122 | | 1999-01-15 | | Expired | United States of America | PMOS Device Having A Layered Silicon Gate For Improved Silicide Integrity And Enhanced Boron Penetration Resistance |

| Method For Benchmarking Thin Film Measurement Tools | United States of America | Granted | 2001-10-16 | 1999-12-17 | 6303397 | 09466285 |
|---|--------------------------|-------------|------------|------------|----------|---------------|
| A Barrier Layer For Interconnect Structures Of A Semiconductor Wafer And Method For Depositing The Barrier Layer | United States of America | Lapsed | 2006-07-04 | 2001-09-28 | 7071563 | 09967094 |
| Shallow junction formation | United States of America | Granted | 2004-01-20 | 2001-06-29 | 6680243 | 09897517 |
| Dynamic edge bead removal | United States of America | Granted | 2007-02-27 | 2004-09-27 | 7183181 | 10950839 |
| Damascene Capacitors For Integrated Circuits | United States of America | Granted | 2001-08-07 | 1999-04-15 | 6271596 | 09292422 |
| Method For Making An Integrated Circuit Including High And Low Voltage Transistors | United States of America | Granted | 2001-03-27 | 1999-07-29 | 6207510 | 09363769 |
| Fabrication | United States of America | Granted | 2003-03-25 | 2000-08-02 | 6537867 | 09630463 |
| High Speed Low Voltage Semiconductor Devices And Method Of | | | | | | |
| Method For Separating A Semiconductor Wafer Into Individual Semiconductor Dies Using An Implanted Impurity | China | Application | | 2007-05-17 | | 2015105007177 |
| Method For Separating A Semiconductor Wafer Into Individual Semiconductor Dies Using An Implanted Impurity | China | Abandoned | | 2007-05-17 | | 2007800530078 |
| Method And System For Eliminating Extrusions In Semiconductor Vias | United States of America | Granted | 2004-04-13 | 2000-06-02 | 6720261 | 09586586 |
| Method Of Coil Preparation For Ionized Metal Plasma Process And Method Of Manufacturing Integrated Circuits | United States of America | Granted | 2004-03-02 | 2001-04-16 | 6699372 | 09836365 |
| Method And Apparatus For Manufacturing Multiple Circuit Patterns Using A Multiple Project Mask | United States of America | Lapsed | 2009-08-25 | 2003-06-30 | 7581203 | 10610002 |
| Method For Separating A Semiconductor Wafer Into Individual Semiconductor Dies Using An Implanted Inpurity | United States of America | Granted | 2012-02-21 | 2009-11-16 | 8119501 | 12618936 |
| Multiple Purpose Reticle Layout For Selectively Printing | United States of America | Expired | | 2001-08-15 | | 60312389 |
| Fully\(milsolated Thin\\(miFilm Trench Capacitor | United States of America | Expired | | 1998-07-07 | | 60091896 |
| Process for inhibiting crack formation in low dielectric constant dielectric films of integrated circuit structure | United States of America | Granted | 2002-07-16 | 2000-11-01 | 6420277 | 09704635 |
| Formation Of An Integrated Circuit Structure With Reduced Dishing In Metallization Levels | United States of America | Expired | | 2006-01-04 | | 60756056 |
| A Semiconductor Device Having A Metal Barrier Layer For A Dielectric Material Having A High Dielectric Constant And A Method Of Manufacture Thereof | United States of America | Granted | 2002-06-11 | 2000-01-11 | 6403415 | 09481463 |
| Method Of Electrical Probing | United States of America | Expired | | 2004-07-29 | | 60592153 |
| Mask And Implant Savings For Dual Voltage CMOS Technologies | United States of America | Expired | | 1999-01-12 | | 60115718 |
| Compound, High K, Gate And Capacitor Insulator Layer | United States of America | Expired | | 1996-12-23 | | 60033839 |
| Process For Forming Patterned Dielectric Oxide Films | United States of America | Granted | 1999-11-02 | 1998-04-07 | 5976625 | 09056133 |
| Methodology to measure many more transistors on the same test area | United States of America | Granted | 2007-03-13 | 2003-10-29 | 7190185 | 10696320 |
| A Process For Forming Patterned Dielectric Oxide Films | United States of America | Expired | | 1997-04-11 | | 60043235 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Chemical-Mechanical Polishing Apparatus And Method | United States of America | Granted | 2000-08-29 | 1998-12-24 | 6110012 | 09220417 |
|--|-------------------------------|---------|------------|------------|----------|----------|
| Mask Repair | United States of America | Granted | 2002-04-09 | 1999-08-27 | 6368753 | 09384395 |
| Chemical Mechanical Polishing Composition And Method Of Polishing Metal Layers Using Same | United States of America | Granted | 2003-07-29 | 2000-02-29 | 6599837 | 09515730 |
| Low gate resistance layout procedure for RF transistor devices | United States of America | Lapsed | 2005-10-25 | 2003-07-25 | 6958541 | 10627289 |
| Chemical Mechanical Polishing Of Dual Orientation Polycrystalline Materials | United States of America | Lapsed | 2005-05-31 | 2002-04-12 | 6899596 | 10121370 |
| Dielectric Materials Of Amorphous Compositions And Devices Employing Same | United States of America | Expired | 1999-06-15 | 1997-09-24 | 5912797 | 08936132 |
| CMOS Vertical Replacement Gate (VRG) Transistors | United States of America | Granted | 2004-08-10 | 2001-12-26 | 6773994 | 10036020 |
| Substrate | United States of America | Granted | 1999-12-28 | 1997-11-04 | 6008123 | 08963687 |
| | United States of America | Lapsed | 2006-08-01 | 2003-10-29 | 7084408 | 10697507 |
| Vanctization and ionization of motals for use in coming adjuster | Officed States of Afficiation | Granted | 5000-09-19 | 1998-03-12 | 9121101 | 09042388 |
| Architecture For Circuit Connection Of A Vertical Transistor | ᆡᄋᆠ | Granted | 2005-06-07 | 2000-08-25 | 6903411 | 09648164 |
| Standardized Test Board For Testing Custom Chips | United States of America | Granted | 2002-08-06 | 1999-10-04 | 6430047 | 09412089 |
| Article Comprising A Variable Inductor | United States of America | Granted | 2001-02-06 | 1999-07-16 | 6184755 | 09354711 |
| Wafer edge inspection data gathering | United States of America | Lapsed | 2006-03-14 | 2003-09-12 | 7013222 | 10661013 |
| Process yield learning | United States of America | Lapsed | 2006-09-26 | 2003-10-29 | 7114143 | 10696203 |
| Method For Making Integrated Circuit Capacitor Including Anchored Plug | United States of America | Granted | 2001-01-02 | 1999-07-30 | 6169010 | 09364208 |
| Process for planarizing upper surface of damascene wiring structure for integrated circuit structures | United States of America | Granted | 2005-04-19 | 2003-07-07 | 6881664 | 10614776 |
| Aluminum Pad Power Bus And Signal Routing For Integrated Circuit Devices Utilizing Copper Technology Interconnect Structures | United States of America | Granted | 2009-07-28 | 2003-09-30 | 7566964 | 10675258 |
| Method To Avoid Copper Contamination Of A Via Or Dual Damascene Structure | United States of America | Granted | 2006-02-28 | 2002-09-30 | 7005375 | 10260727 |
| Integrated Circuit Including Passivated Copper Interconnection Lines And Associated Manufacturing Methods | United States of America | Granted | 2002-08-27 | 1999-07-30 | 6440852 | 09364858 |
| Methods Of Fabricating An Integrated Circuit Device With Composite Oxide Dielectric | United States of America | Granted | 2001-05-22 | 1999-06-25 | 6235594 | 09340224 |
| PMOS Device Having A Layered Silicon Gate For Improved Silicide Integrity And Enhanced Boron Penetration Resistance | United States of America | Granted | 2001-11-06 | 1999-10-12 | 6313021 | 09416491 |
| Charge Injection Transistor Using High-K Dielectrics Barrier Layer | United States of America | Granted | 2001-10-16 | 1999-06-25 | 6303940 | 09339894 |
| Method Of Chemical Vapor Depositing Tungsten Films | United States of America | Granted | 2001-09-25 | 2000-03-03 | 6294468 | 09517965 |
| Integrated Circuit Device Having Dual Damascene Capacitor | United States of America | Granted | 2001-11-20 | 1999-09-02 | 6320244 | 09388682 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Capacitor For An Integrated Circuit | United States of America | Granted | 2004-04-13 | 1999-02-16 | 6720604 | 09250500 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Electrostatic Discharge Protection Device With Monolithically Formed Resistor-Capacitor Portion | United States of America | Granted | 2002-05-07 | 2000-07-17 | 6384452 | 09617687 |
| Reduction In Damage To Optical Elements Used In Optical Lithography For Device Fabrication | United States of America | Expired | 1999-04-06 | 1996-01-16 | 5891605 | 08586412 |
| Integrated Circuit And A Method Of Manufacturing An Integrated Circuit | United States of America | Lapsed | 2004-12-21 | 2000-06-27 | 6833557 | 09604519 |
| Thin Film Transistor And Organic Semiconductor Material Therefor | United States of America | Expired | 1999-08-10 | 1997-10-16 | 5936259 | 08951779 |
| Lithographic Process For Device Fabrication Using A Multilayer Mask Which Has Been Previously Inspected | United States of America | Granted | 2000-03-28 | 1997-12-09 | 6042995 | 08987491 |
| Electrostatic Protection Devices For Protecting Semiconductor Integrated Circuitry | United States of America | Expired | 1998-04-28 | 1995-11-20 | 5744840 | 08560671 |
| Spaced-Gate Emission Device And Method For Making Same | United States of America | Expired | 1996-04-02 | 1994-08-31 | 5504385 | 08299470 |
| Stacked Structure For Parallel Capacitors And Method Of Fabrication | United States of America | Granted | 2005-01-04 | 2000-08-31 | 6838717 | 09653295 |
| Imaging Active Pixel Device Having A Non-Destructive Read-Out Gate | United States of America | Expired | 1996-07-30 | 1994-10-17 | 5541402 | 08323945 |
| Area-Efficient Layout For High Voltage Lateral Devices | United States of America | Expired | 1996-07-09 | 1994-11-30 | 5534721 | 08346706 |
| Method of Manufacturing An Integrated Circuit | United States of America | Granted | 2002-10-01 | 2000-08-30 | 6458669 | 09650606 |
| Method of Using A Getter Layer To Improve Metal To Metal Contact Resistance At Low Radio Frequency Power | United States of America | Expired | 1999-11-23 | 1997-10-07 | 5989984 | 08946413 |
| Method of mapping logic failures in an integrated circuit die | United States of America | Lapsed | 2006-01-10 | 2003-07-28 | 6986112 | 10628986 |
| Process For Forming Integrated Structures Using Three Dimensional Printing Techniques | United States of America | Granted | 2002-04-02 | 1998-10-16 | 6363606 | 09174503 |
| Automatic Compound Shaking Machine | United States of America | Granted | 2001-03-27 | 1999-11-30 | 6206054 | 09451078 |
| Mechanism for improving the structural integrity of low-k films | United States of America | Granted | 2006-01-03 | 2003-10-02 | 6982206 | 10679004 |
| Structure And Method For Adjusting Integrated Circuit Resistor Value | United States of America | Granted | 2007-02-13 | 2004-09-29 | 7176781 | 10953478 |
| Method Of Passivating Copper Interconnects In A Semiconductor | United States of America | Granted | 2000-06-06 | 1999-06-23 | 6071808 | 09339085 |
| Wafer edge defect inspection using captured image analysis | United States of America | Granted | 2011-06-28 | 2003-07-28 | 7968859 | 10628614 |
| Integrated Circuit Fabrication | United States of America | Granted | 1999-09-21 | 1998-03-03 | 5955381 | 09034079 |
| Method Of Monitoring A Patterned Transfer Process Using Line Width Metrology | United States of America | Granted | 2001-05-01 | 1999-08-27 | 6225639 | 09384459 |
| A Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And An Integrated Circuit | United States of America | Granted | 2002-04-02 | 1999-08-30 | 6365327 | 09386065 |
| GaAs-Based MOSFET, And Method Of Making Same | United States of America | Expired | 1999-05-11 | 1997-02-24 | 5903037 | 08804782 |
| Metal-Oxide-Semiconductor Device Having An Enhanced Shielding Structure | United States of America | Lapsed | 2006-08-08 | 2004-08-18 | 7087959 | 10920656 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Electrochemical Generation Of Silane | United States of America | Expired | 1996-04-23 | 1994-08-31 | 5510007 | 08299701 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Method And Apparatus For Imaging Semiconductor Devices | United States of America | Expired | 2001-11-13 | 1997-05-15 | 6316950 | 08856561 |
| Pattern Delineating Apparatus For Use In The EUV Spectrum | United States of America | Expired | 1996-05-28 | 1994-10-20 | 5521031 | 08326449 |
| Articles Comprising Magnetically Soft Thin Films And Methods For Making Such Articles | United States of America | Expired | 1998-07-14 | 1996-02-02 | 5780175 | 08595543 |
| Polycide Gate Structure With Intermediate Barrier | United States of America | Granted | 2000-11-14 | 1997-11-24 | 6147388 | 08977318 |
| Self-Aligned Contact Window | United States of America | Expired | 1999-03-09 | 1991-12-30 | 5880022 | 07815316 |
| Method of Fabricating Gate Stack Having a Reduced Height | United States of America | Expired | 1995-08-01 | 1994-01-03 | 5438006 | 08176600 |
| Wafer Processing Using Thermal Nitride Etch Mask | United States of America | Expired | 1998-01-27 | 1995-09-20 | 5711891 | 08531115 |
| Article Comprising A Multiport Variable Capacitor | United States of America | Granted | 2001-06-05 | 1998-09-12 | 6242989 | 09152185 |
| Article Comprising A Bipolar Transistor With Floating Base | United States of America | Expired | 1995-10-24 | 1994-08-24 | 5461245 | 08295303 |
| Nanoscale Conductive Connectors And Method For Making Same | United States of America | Granted | 2001-11-27 | 1999-07-15 | 6322713 | 09354928 |
| Method of Depositing Thin Passivating Film on Microminiature Semiconductor Devices | United States of America | Expired | 1997-04-15 | 1995-12-04 | 5620909 | 08566766 |
| Integrated Circuit with Interlevel Dielectric | United States of America | Expired | 1996-09-24 | 1994-12-29 | 5559052 | 08366192 |
| Capacitive Element | United States of America | Expired | 1998-05-19 | 1996-10-22 | 5754392 | 08735170 |
| Article Comprising A Relatively Temperature-Insensitive Ta-Oxide Based | | | | | | |
| Semiconductor Device Having Sell-Aligned Contact And Landing PAD Structure And Method Of Forming Same | United States of America | Granted | 2002-11-19 | 1999-11-30 | 6483144 | 09451054 |
| Planar Magnetic Frame Inductors Having Open Cores | United States of America | Granted | 2003-06-03 | 2000-03-31 | 6573818 | 09540618 |
| Method For Forming Vias in a Low Dielectric Constant Material | United States of America | Granted | 2001-01-30 | 1999-10-29 | 6180518 | 09430226 |
| CMP Slurry For Polishing Semiconductor Wafers And Related Methods | United States of America | Granted | 2002-10-01 | 1999-10-06 | 6458289 | 09413742 |
| Deuterium Passivated Semiconductor Device Having Enhanced Immunity To Hot Carrier Effects | United States of America | Granted | 2004-01-06 | 1999-08-23 | 6674151 | 09379055 |
| Method For Processing Silicon Workpieces Using Hybrid Optical Thermometer System | United States of America | Granted | 2004-12-14 | 1999-04-06 | 6830942 | 09286929 |
| A Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And An Integrated Circuit | United States of America | Granted | 2001-11-06 | 1999-08-30 | 6313025 | 09385165 |
| Process For Device Fabrication In Which A Thin Layer Of Cobalt Silicide Is Formed | United States of America | Expired | 1998-03-17 | 1996-04-04 | 5728625 | 08627560 |
| Insitu Dry Cleaning Process For Poly Gate Etch | United States of America | Granted | 2001-03-06 | 1998-01-20 | 6197699 | 09009399 |
| Method Of Reducing Dielectric Damage From Plasma Etch Charging | United States of America | Expired | 1998-12-01 | 1996-09-30 | 5843827 | 08724128 |
| Uniformity And Method For Making The Same | United States of America | Granted | 2002-09-10 | 1999-06-22 | 6448569 | 09337741 |
| Ronded Article Having Improved Crystalline Structure And Work Function | | 1 | | 1 | 1 | |
| Method To Selectively Heat Semiconductor Wafers | United States of America | Granted | 2001-06-12 | 1999-11-23 | 6245692 | 09448349 |
| Wafer Holder For Thermal Processing Apparatus | United States of America | Expired | 1999-01-26 | 1996-07-31 | 5863843 | 08692836 |
| Selective Isotropic Etch For Titanium Based Materials | United States of America | Lapsed | 2006-07-18 | 2003-09-30 | 7078337 | 10675263 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| ווויר לי מורמ ביו במור ו מצו ובמנוסוו | | гарзеи | 11-00-11 | 1222-02-20 | ZOCOCT-INI | 00102333 |
|---|--------------------------|----------|------------|------------|------------|----------|
| Integrated Circuit Eabrication | | Lapsod . | | 1000-07-76 | NII_120267 | 00103035 |
| Damascene Capacitors For Integrated Circuits | Taiwan | Lapsed | 2002-05-11 | 2000-01-10 | NI-155124 | 89100250 |
| A Gate Stack Structure For Integrated Circuit Fabrication | Taiwan | Granted | 2001-12-01 | 2000-05-15 | NI-145230 | 89109252 |
| Charge Injection Transistor Using High-K Dielectrics Barrier Layer | Taiwan | Lapsed | 2003-03-01 | 2000-05-15 | NI-172855 | 89109253 |
| An Inductor Or Low Loss Interconnect In An Integrated Circuit | Taiwan | Granted | 2003-09-01 | 2000-02-18 | NI-186701 | 88119230 |
| An Inductor Or Low Loss Interconnect And A Method Of Manufacturing | | | | | | |
| CMOS Vertical Replacement Gate (VRG) Transistors | Taiwan | Lapsed | 2004-01-14 | 2002-08-22 | NI-185928 | 91119023 |
| Electron Emitters for Lithography Tools | Taiwan | Lapsed | 2004-06-11 | 2000-07-15 | NI-203326 | 89108620 |
| High Quality Oxide For Use In Integrated Circuits | Taiwan | Lapsed | 2004-03-21 | 2000-09-20 | NI-198319 | 89112402 |
| them | United States of America | Granted | 2004-11-09 | 2001-11-27 | 6815342 | 09996118 |
| Lithographic Method Utilizing A Phase-Shifting Mask | United States of America | Granted | 2002-08-20 | 2000-01-20 | 6436608 | 09488355 |
| Polishing Carrier Head | | Granted | 2004-04-27 | 2000-04-21 | 6726537 | 09553931 |
| Method For Making A Semiconductor Device | | Granted | 2001-08-14 | 2000-01-18 | 6274409 | 09484759 |
| Device Comprising Bipolar Semi-Conducting Film | United States of America | Granted | 2002-08-06 | 2000-04-06 | 6429040 | 09543808 |
| Apparatus for Detecting Masma Etch Endpoint in Semiconductor Fabrication And Associated Method | United States of America | Granted | 2002-03-19 | 1999-11-03 | 6358359 | 09432926 |
| Self Alignbed Gated Schottky Diode Guard Ring Structures | United States of America | Granted | 2002-06-04 | 2000-04-18 | 6399413 | 09551050 |
| Calibration Method For Quantitative Elemental Analysis | | Granted | 2003-08-05 | 2000-05-09 | 6603119 | 09567675 |
| A Method Of Fabricating An Integrated Circuit | United States of America | Granted | 2002-06-18 | 2000-02-25 | 6406609 | 09513390 |
| Thin Film Transistors | United States of America | Granted | 2000-10-24 | 1999-11-29 | 6136702 | 09450525 |
| Sputtering System | United States of America | Granted | 2002-01-29 | 2000-02-11 | 6342134 | 09503225 |
| Method For Producing Piezoelectric Films With Rotating Magnetron | | | | | | |
| Integrated Circuit with Gate Conductor Defined Resistor | United States of America | Expired | 1998-11-17 | 1993-09-08 | 5838033 | 08118109 |
| Inductor for High Frequency Circuits | United States of America | Expired | 1996-09-24 | 1994-12-19 | 5559360 | 08359309 |
| Acoustic Analysis Of Gas Mixtures | United States of America | Expired | 1997-04-29 | 1995-12-12 | 5625140 | 08570906 |
| Method of Integrated Circuit Fabrication | United States of America | Expired | 2000-02-01 | 1996-12-18 | 6020256 | 08769605 |
| Method Of Making In-Containing III/V Semiconductor Devices | United States of America | Expired | 1996-06-18 | 1995-07-21 | 5527425 | 08505047 |
| Process For Dry Lithographic Etching | United States of America | Expired | 1999-09-07 | 1995-05-26 | 5948570 | 08451283 |
| A Process For Fabricating A Device In Which The Process Is Controlled By Near-Field Imaging Latent Features Introduced Into Energy Sensitive Resist Materials | United States of America | Expired | 1997-08-12 | 1995-02-21 | 5656182 | 08391905 |
| Temperature Coefficient | United States of America | Expired | 1997-08-19 | 1995-10-03 | 5658485 | 08538318 |
| Integrated Circuit Fabrication | United States of America | Expired | 1997-11-18 | 1995-11-30 | 5688704 | 08565286 |
| Method Of Making A P-Channel Bipolar Transistor | | Expired | 1998-03-17 | 1996-11-20 | 5728607 | 08754607 |
| Device And Method For Polishing A Semiconductor Substrate | United States of America | Granted | 2000-04-18 | 1998-05-19 | 6051500 | 09080992 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
| | | | | | | |

| Fabricating High-Q RF Component | Taiwan | Granted | 2002-04-08 | 2000-05-24 | NI-146566 | 89103722 |
|---|--------------------------|---------|------------|------------|-----------|-----------|
| A Capacitor For Integration With Copper Damascene Processes | Taiwan | Lapsed | 2002-06-21 | 2001-01-15 | NI-151372 | 90100857 |
| Vertical Replacement Gate (VRG) MOSFET With A Conductive Layer Adjacent A Source/Drain Region And Method Of Manufacture Therefor | United States of America | Granted | 2003-02-11 | 2000-03-20 | 6518622 | 09528753 |
| Articles Comprising Magnetically Soft Thin Films And Methods For Making Such Articles | Taiwan | Expired | 1999-11-02 | 1997-01-21 | NI-104341 | 86100615 |
| Bipolar Tranistor Having A Low K Material In The Emitter Region | United States of America | Lapsed | 2003-12-02 | 2000-08-03 | 6657281 | 09631755 |
| Method And Apparatus For Imaging Semiconductor Devices | Taiwan | Lapsed | 1999-09-11 | 1998-04-09 | NI-106777 | 87105344 |
| Method Of Mechanical Polishing | Taiwan | Lapsed | 2000-08-01 | 1998-09-29 | NI-118398 | 87114709 |
| Insitu Dry Cleaning Process For Poly Gate Etch | Taiwan | Lapsed | 2001-09-03 | 1998-12-21 | NI-131816 | 87121335 |
| Thin Film Transistors | Taiwan | Granted | 2001-04-20 | 1999-06-22 | NI-124018 | 88110493 |
| Process For Device Fabrication | Taiwan | Lapsed | 2000-02-21 | 1998-07-13 | NI-111955 | 87111331 |
| For Forming The Inductor | Taiwan | Lapsed | 2013-10-11 | 2004-06-29 | 1412119 | 093119217 |
| A Spiral Inductor Formed In A Semiconductor Substrate And A Method | | | | | | |
| Interdigitated Capacitor Structure For Use In An Integrated Circuit | United States of America | Granted | 2002-05-07 | 2000-02-16 | 6383858 | 09505762 |
| Chemical-Mechanical Polishing Apparatus And Method | Taiwan | Granted | 2002-01-01 | 1999-11-10 | NI-147721 | 88119654 |
| Damascene Structure And An Integrated Circuit | Taiwan | Lapsed | 2002-09-11 | 2000-06-15 | NI-162650 | 89111675 |
| A Process For Manufacturing An Integrated Circuit Including A Dual- | | 1 | | | | |
| A Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And An Integrated Circuit | Taiwan | Lapsed | 2002-08-11 | 2000-06-14 | NI-160919 | 89111610 |
| A Multi-Layer Inductor Formed In A Semicondutor Substrate | Taiwan | Lapsed | 2004-02-16 | 2002-09-13 | NI-189019 | 91121020 |
| Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And A Capacitor | Taiwan | Lapsed | 2006-06-11 | 2001-06-12 | 1256683 | 90114096 |
| Uniformity And Method For Making The Same | Taiwan | Lapsed | 2001-05-01 | 2000-06-22 | NI-131524 | 89112268 |
| And Method For Depositing The Barrier Layer | Taiwan | Granted | 2003-09-18 | 2002-01-30 | NI-178411 | 91101551 |
| A Barrier Layer For Interconnect Structures Of A Semiconductor Wafer | | 3 | 1 | 1000 | | |
| Architecture For Circuit Connection Of A Vertical Transistor | Taiwan | Lapsed | 2006-08-21 | 2001-08-29 | 1260734 | 90121536 |
| Method Ot Manufacturing An Integrated Circuit Using The Chemical Mechanical Polisher | United States of America | Granted | 2003-02-11 | 2000-01-05 | 6517416 | 09477833 |
| A Chemical Mechancial Polisher Including A Pad Conditioner And A | | | | | | |
| Simplified High Q Inductor Substrate | Taiwan | Granted | 2001-05-28 | 1999-11-30 | NI-132577 | 88119226 |
| Method and apparatus for measuring sheet resistance | United States of America | Lapsed | 2005-03-22 | 2003-10-23 | 6870386 | 10691938 |
| Method To Improve Metal Defects In Semiconductor Device Fabrication | United States of America | Granted | 2011-07-19 | 2006-06-29 | 7982286 | 11427494 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method To Improve Metal Defects In Semiconductor Device Fabrication | Korea, Republic of (KR) | Lapsed | 2014-01-29 | 2007-06-29 | 10-1359555 | 1020070065264 |
|---|--------------------------|---------|------------|------------|------------|---------------|
| A Gate Stack Structure For Integrated Circuit Fabrication | Korea, Republic of (KR) | Granted | 2007-10-10 | 2000-06-26 | 767610 | 1020000035368 |
| Fabricating High-Q RF Component | Korea, Republic of (KR) | Granted | 2006-07-20 | 2000-03-02 | 605779 | 20000010425 |
| A Capacitor For Integration With Copper Damascene Processes | Korea, Republic of (KR) | Lapsed | 2004-04-20 | 2001-01-19 | 429726 | 20010003082 |
| Electronic Apparatus | Korea, Republic of (KR) | Granted | 2003-01-27 | 1999-01-20 | 371623 | 1019990001574 |
| Dielectric Materials | Korea, Republic of (KR) | Granted | 2001-12-20 | 1999-03-11 | 319571 | 1019990008028 |
| A Process For Making Electronic Components With Doped Metal Oxide | | | | | | |
| Electronic Components With Doped Metal Oxide Dielectric Materials And | | | | | | |
| Membrane Mask for Projection Lithography | Korea, Republic of (KR) | Lapsed | 2001-10-19 | 1999-04-02 | 0313423 | 19990011551 |
| Doped Base | Korea, Republic of (KR) | Lapsed | 2006-04-07 | 1999-07-31 | 570910 | 1019990031535 |
| Silicon Germanium Heterostructure Bipolar Transistor With Indium | | | | | | |
| Damascene Capacitors For Integrated Circuits | Korea, Republic of (KR) | Granted | 2006-12-12 | 2000-01-10 | 10-0658954 | 1020000000859 |
| Integrated Circuit Device Having Dual Damascene Capacitor | Korea, Republic of (KR) | Lapsed | 2007-03-08 | 2000-01-11 | 695026 | 1020000001148 |
| Calibration Method For Quantitative Elemental Analysis | Korea, Republic of (KR) | Lapsed | 2004-08-10 | 2001-05-09 | 445020 | 1020010025174 |
| Method of Manufacturing An Integrated Circuit | Korea, Republic of (KR) | Lapsed | 2008-07-14 | 2001-08-30 | 847233 | 1020010052995 |
| Method for incorporating germanium into a semiconductor wafer | United States of America | Granted | 2007-08-28 | 2003-04-25 | 7262119 | 10423184 |
| High-k dielectric bird's beak optimizations using in-situ O2 plasma oxidation | United States of America | Granted | 2004-06-08 | 2003-03-25 | 6746925 | 10397451 |
| Deuterated Bipolar Transistors And Method Of Manufacture Thereof | Korea, Republic of (KR) | Lapsed | 2002-03-09 | 1998-04-28 | 329580 | 1019980015165 |
| Method And Apparatus For Imaging Semiconductor Devices | Korea, Republic of (KR) | Lapsed | 2000-08-21 | 1998-05-15 | 271843 | 9817633 |
| Dose Modification Proximity Effect Compensation (PEC) Technique For Electron Beam Lithography | Korea, Republic of (KR) | Expired | 2000-10-26 | 1997-06-07 | 279034 | 19970024048 |
| Integrated Circuit Conductors That Avoid Current Crowding | Korea, Republic of (KR) | Lapsed | 2003-04-03 | 1998-11-17 | 380514 | 9849182 |
| Method For Removing Etching Residues And Contaminants | Korea, Republic of (KR) | Lapsed | 2002-07-24 | 1998-11-26 | 347648 | 9850861 |
| Thin Film Tantalum Oxide Capacitors And Resulting Product | Korea, Republic of (KR) | Lapsed | 2001-03-26 | 1998-03-04 | 292707 | 987041 |
| Thin Film Transistors | Korea, Republic of (KR) | Lapsed | 2007-01-05 | 1999-08-20 | 667603 | 1019990034561 |
| Method For Forming Vias in a Low Dielectric Constant Material | Korea, Republic of (KR) | Lapsed | 2007-08-31 | 2000-10-27 | 756200 | 1020000063481 |
| Process For Fabricating Bipolar And BICMOS Devices | Korea, Republic of (KR) | Lapsed | 2006-02-01 | 1999-03-11 | 549974 | 1019990008029 |
| A Lithographic Process Having Sub-Wavelength Resolution | Korea, Republic of (KR) | Granted | 2006-08-16 | 2000-04-15 | 614781 | 1020000019775 |
| Method For Making A Semiconductor Device | Korea, Republic of (KR) | Lapsed | 2007-01-25 | 2001-01-18 | 676643 | 20010002872 |
| High Quality Oxide For Use In Integrated Circuits | Korea, Republic of (KR) | Granted | 2007-06-27 | 2000-06-24 | 734757 | 1020000035106 |
| High Resistivity Film For 4T SRAM | United States of America | Granted | 2003-07-01 | 1999-08-27 | 6586310 | 09384631 |
| Bipolar Tranistor Having A Low K Material In The Emitter Region | Taiwan | Granted | 2002-11-21 | 2001-08-02 | 01-169919 | 90118908 |
| CMP System For Polishing Semiconductor Wafers And Related Method | United States of America | Granted | 2002-08-20 | 1999-10-06 | 6436830 | 09413741 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Calibration Method For Quantitative Elemental Analysis | Taiwan | Lapsed | 2004-06-21 | 2001-05-08 | NI-203745 | 90110939 |
|--|--------------------------|---------|------------|------------|------------|---------------|
| High Quality Oxide For Use In Integrated Circuits | Japan | Granted | 2005-11-04 | 2000-06-23 | 3737341 | 2000190017 |
| Method of Manufacturing An Integrated Circuit | Japan | Lapsed | 2007-12-28 | 2001-08-30 | 4058710 | 2001260998 |
| Method Of Reducing Dielectric Damage From Plasma Etch Charging | Japan | Lapsed | 2002-06-07 | 1997-09-22 | 3315064 | 09256542 |
| Process For Device Fabrication In Which A Thin Layer Of Cobalt Silicide Is Formed | Japan | Expired | 2004-09-24 | 1997-04-04 | 3600399 | 09085442 |
| Method of Depositing Thin Passivating Film on Microminiature Semiconductor Devices | Japan | Expired | 2001-08-31 | 1996-11-26 | 3226808 | 08314671 |
| Lid liner for chemical vapor deposition chamber | United States of America | Lapsed | 2005-06-28 | 2003-06-02 | 6911093 | 10453821 |
| Lithographic Process For Device Fabrication Using A Multilayer Mask Which Has Been Previously Inspected | Japan | Lapsed | 2001-10-19 | 1998-12-09 | 3242079 | 10349957 |
| Integrated Circuit Device Having Dual Damascene Capacitor | Taiwan | Lapsed | 2002-03-06 | 2000-01-11 | NI-144338 | 89100359 |
| Barrier For Copper Metallization | Taiwan | Granted | 2001-11-21 | 2000-02-11 | NI-144804 | 88122552 |
| GaAs-Based MOSFET, And Method Of Making Same | Japan | Lapsed | 2001-05-11 | 1998-02-24 | 3187764 | 10041685 |
| Real-Time Gate Etch Critical Dimension Control By Oxygen Monitoring | Korea, Republic of (KR) | Lapsed | 2011-06-23 | 2004-09-30 | 10-1045194 | 1020040077975 |
| A Multi-Layer Inductor Formed In A Semicondutor Substrate | Korea, Republic of (KR) | Lapsed | 2010-01-25 | 2002-10-04 | 10-939648 | 1020020060412 |
| Metal-Oxide-Semiconductor Device Having An Enhanced Shielding Structure | Korea, Republic of (KR) | Lapsed | 2012-09-12 | 2005-08-18 | 10-1184123 | 20050075648 |
| Metal-Oxide Semiconductor Device Having Improved Performance And Reliability. | Korea, Republic of (KR) | Lapsed | 2011-06-20 | 2004-10-15 | 10-1044528 | 20040082410 |
| Vertical Replacement-Gate Junction Field-Effect Transistor | Taiwan | Lapsed | 2004-02-12 | 2002-08-30 | NI-188794 | 91119882 |
| Stacked Structure For Parallel Capacitors And Method Of Fabrication | Taiwan | Granted | 2002-12-21 | 2001-08-30 | NI-170349 | 90121470 |
| Dielectric Materials Of Amorphous Compositions And Devices Employing Same | Japan | Lapsed | 2005-02-25 | 1998-09-22 | 3649917 | 10268775 |
| Aluminum Pad Power Bus And Signal Routing For Integrated Circuit Devices Utilizing Copper Technology Interconnect Structures | Korea, Republic of (KR) | Granted | 2011-11-14 | 2004-04-08 | 10-1084957 | 1020040023990 |
| Dual Damascene Bond Pad Structure for Lowering Stress and Allowing Circuitry Under Pads | Japan | Granted | 2008-06-13 | 2000-12-15 | 4138232 | 2000381501 |
| Process For The Fabrication Of Dual Gate Structures For CMOS Devices | Japan | Lapsed | 2004-02-20 | 2000-02-25 | 3524461 | 2000048754 |
| Electron Emitters for Lithography Tools | Japan | Granted | 2003-11-14 | 2000-05-08 | 3492977 | 2000135070 |
| Calibration Method For Quantitative Elemental Analysis | Japan | Granted | 2014-07-09 | 2001-05-09 | 5544677 | 2001138037 |
| Multiple alternating phase shift technology for amplifying resolution | United States of America | Lapsed | 2006-02-21 | 2003-05-09 | 7001695 | 10435442 |
| A Spiral Inductor Formed In A Semiconductor Substrate And A Method For Forming The Inductor | Korea, Republic of (KR) | Granted | 2011-11-14 | 2004-08-20 | 10-1084959 | 1020040065903 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
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| CMOS Vertical Replacement Gate (VRG) Transistors | Japan | Lapsed | | 2002-12-24 | | 2002371914 |
|---|--------------------------|---------|------------|------------|------------|---------------|
| Nethod For Processing Silicon Workpieces Using Hybrid Optical Thermometer System | Japan | Lapsed | 2005-05-13 | 2000-04-06 | 3676183 | 2000104530 |
| | Japan | Lapsed | 2008-09-19 | 2000-10-27 | 4187399 | 2000328233 |
| | Korea, Republic of (KR) | Granted | 2009-12-07 | 2002-09-10 | 10-931816 | 1020020054579 |
| Selective Isotropic Etch For Titanium Based Materials | Korea, Republic of (KR) | Granted | 2012-12-17 | 2004-09-30 | 10-1214818 | 1020040078027 |
| Electron Beam Imaging Apparatus | Korea, Republic of (KR) | Lapsed | 2004-01-29 | 2000-10-06 | 418231 | 20000058700 |
| Simplified High Q Inductor Substrate | Korea, Republic of (KR) | Granted | 2004-11-02 | 2000-08-29 | 456704 | 20000050243 |
| Wafer blade contact monitor | United States of America | Lapsed | 2005-05-10 | 2003-04-09 | 6889818 | 10409859 |
| Nethod and apparatus for filtering a chemical polishing slurry of a water fabrication process | United States of America | Lapsed | 2005-08-16 | 2003-05-08 | 6929532 | 10434028 |
| Polycide Gate Structure With Intermediate Barrier | Korea, Republic of (KR) | Lapsed | 2001-05-15 | 1998-11-23 | 0296859 | 9850222 |
| Lithography line width monitor reflecting chip-wide average feature size | United States of America | Lapsed | 2006-03-21 | 2003-03-31 | 7016054 | 10403611 |
| Charge Injection Transistor Using High-K Dielectrics Barrier Layer | Korea, Republic of (KR) | Lapsed | 2007-02-13 | 2000-06-26 | 684480 | 1020000035302 |
| Chemical-Mechanical Polishing Apparatus And Method | Korea, Republic of (KR) | Lapsed | 2002-03-06 | 1999-12-23 | 329096 | 1019990060855 |
| Process For The Fabrication Of Dual Gate Structures For CMOS Devices | Korea, Republic of (KR) | Lapsed | 2008-04-04 | 2000-02-25 | 821494 | 1020000009286 |
| Article Comprising Fluorinated Diamond-Like Carbon And Method For Fabricating Article | Korea, Republic of (KR) | Lapsed | 2002-04-11 | 1999-03-11 | 333996 | 1019990008027 |
| Modifying contact areas of a polishing pad to promote uniform removal rates | United States of America | Expired | 2001-07-03 | 1997-09-26 | 6254456 | 08938099 |
| Mold For Non-Photolithographic Fabrication Of Microstructures | Korea, Republic of (KR) | Lapsed | 2002-10-09 | 1999-03-24 | 357842 | 19990009959 |
| Vertical Replacement Gate (VRG) MOSFET With A Conductive Layer Adjacent A Source/Drain Region And Method Of Manufacture Therefor | Korea, Republic of (KR) | Lapsed | 2004-06-16 | 2001-03-19 | 0437586 | 20010014032 |
| Methods of Fabricating A Metal-Oxide-Metal Capacitor And Associated Apparatus | Korea, Republic of (KR) | Lapsed | 2008-04-08 | 2001-08-31 | 0822331 | 1020010053374 |
| Architecture For Circuit Connection Of A Vertical Transistor | Korea, Republic of (KR) | Lapsed | 2007-08-07 | 2001-08-25 | 748864 | 1020010053055 |
| Process For Manufacturing An Integrated Circuit Including A Dual- Damascene Structure And A Capacitor | Korea, Republic of (KR) | Lapsed | 2007-06-07 | 2001-06-16 | 727794 | 1020010034116 |
| Electron Emitters for Lithography Tools | Korea, Republic of (KR) | Lapsed | 2006-10-10 | 2000-05-04 | 634727 | 1020000023964 |
| First approximation for OPC significant speed-up | United States of America | Lapsed | 2005-02-08 | 2002-11-27 | 6854104 | 10306067 |
| Circuit And Method For Providing Interconnections Among Individual Integrated Circuit Chips In A Multi-Chip Module | Japan | Lapsed | 2003-03-07 | 1998-04-09 | 3405520 | 10114190 |
| Process For Device Fabrication | Japan | Lapsed | 2004-03-05 | 1998-07-13 | 3529634 | 10197846 |
| Thin Film Transistor And Organic Semiconductor Material Therefor | Japan | Lapsed | 2003-01-10 | 1998-10-16 | 3387832 | 10295074 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| A Gate Stack Structure For Integrated Circuit Fabrication | Japan | Abandoned | | 2000-06-23 | | 2000189026 |
|--|--------------------------|-----------|------------|------------|-------------------|---------------|
| Method To Improve Metal Defects In Semiconductor Device Fabrication | Japan | Lapsed | 2013-10-25 | 2007-06-29 | 5393005 | 2007171578 |
| Laminate low K film | United States of America | Granted | 2005-03-22 | 2002-10-21 | 6869893 | 10277025 |
| Method And Apparatus For Manufacturing Multiple Circuit Patterns Using A Multiple Project Mask | China | Granted | 2009-10-14 | 2004-05-14 | ZL 200410043256.7 | 2004100432567 |
| Process for planarizing an isolation structure in a substrate | United States of America | Granted | 2002-11-19 | 2000-09-27 | 6482075 | 09670998 |
| Thin gate dielectric for a CMOS transistor and method of fabrication thereof | United States of America | Lapsed | 2005-02-01 | 2002-10-30 | 6849512 | 10283630 |
| A Spiral Inductor Formed In A Semiconductor Substrate And A Method For Forming The Inductor | China | Lapsed | 2010-08-18 | 2004-08-04 | ZL200410055847.6 | 2004100558476 |
| Method To Improve Metal Defects In Semiconductor Device Fabrication | China | Lapsed | 2011-06-01 | 2007-06-28 | ZL200710127028.1 | 2007101270281 |
| Metal-Oxide-Semiconductor Device Having An Enhanced Shielding Structure | China | Lapsed | 2009-05-06 | 2005-05-13 | ZL 200510070266.4 | 2005100702664 |
| Self Alignbed Gated Schottky Diode Guard Ring Structures | Japan | Lapsed | 2013-07-26 | 2001-04-18 | 5321933 | 2001119052 |
| Polysilicon gate salicidation | United States of America | Granted | 2003-04-08 | 2002-09-20 | 6544829 | 10251016 |
| Integrated Circuit Package Having Partially Exposed Conductive Layer | Japan | Granted | 2009-08-07 | 2001-07-19 | 4352365 | 2001218921 |
| Device Comprising Bipolar Semi-Conducting Film | Japan | Lapsed | 2012-07-13 | 2001-04-06 | 5036101 | 2001108267 |
| Aluminum Pad Power Bus And Signal Routing For Integrated Circuit Devices Utilizing Copper Technology Interconnect Structures | Japan | Lapsed | | 2004-04-09 | | 2004114863 |
| Lens Array For Electron Beam Lithography Tool | Japan | Granted | 2006-12-22 | 2000-10-10 | 3895535 | 2000309801 |
| Metal-Oxide-Semiconductor Device Having An Enhanced Shielding Structure | Japan | Lapsed | 2012-10-19 | 2005-08-18 | 5111744 | 2005237420 |
| Real-Time Gate Etch Critical Dimension Control By Oxygen Monitoring | Japan | Lapsed | 2012-08-31 | 2004-09-27 | 5073159 | 2004278665 |
| Adaptive Sem edge recognition algorithm | United States of America | Granted | 2007-01-30 | 2002-12-20 | 7171047 | 10327452 |
| Optimization of die yield in a silicon wafer sweet spot | United States of America | Lapsed | 2005-12-27 | 2002-12-30 | 6980917 | 10334430 |
| Method And Apparatus For Imaging Semiconductor Devices | Japan | Lapsed | 2001-08-03 | 1998-05-15 | 3217750 | 10132894 |
| A Multi-Layer Inductor Formed In A Semicondutor Substrate | Japan | Granted | 2012-01-13 | 2002-10-04 | 4903971 | 2002291750 |
| Method For Producing Devices Having Piezoelectric Films | Japan | Lapsed | 2012-02-03 | 2001-02-08 | 4917711 | 2001032114 |
| Membrane Mask for Projection Lithography | Japan | Lapsed | 2003-03-14 | 1999-04-08 | 3408990 | 11100764 |
| Polycide Gate Structure With Intermediate Barrier | Japan | Lapsed | 2002-05-17 | 1998-11-24 | 3306804 | 10333150 |
| Process For Fabricating Vertical Transistors | Japan | Granted | 2003-12-26 | 1999-08-27 | 3506965 | 11240663 |
| Charge Injection Transistor Using High-K Dielectrics Barrier Layer | Japan | Lapsed | 2008-04-11 | 2000-06-23 | 4108252 | 2000189020 |
| Electrostatic Discharge Protection Device With Monolithically Formed Resistor-Capacitor Portion | Japan | Lapsed | 2012-02-24 | 2001-07-17 | 4931296 | 2001217199 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Direct positive image photo-resist transfer of substrate design | United States of America | Granted | 2005-03-29 | 2002-09-25 | 6872321 | 10254708 |
|---|--------------------------|-----------|------------|------------|----------------|---------------|
| Method of reducing leakage using Si3N4 or SiON block dielectric films | United States of America | Granted | 2004-06-01 | 2002-06-05 | 6743669 | |
| Low leakage PMOS on-chip decoupling capacitor cells compatible with standard CMOS cells | United States of America | Granted | 2003-08-19 | 2002-06-04 | 6608365 | 10163120 |
| Optical intensity modifier | United States of America | Granted | 2002-12-24 | 2001-06-11 | 6498045 | 09878741 |
| Direct current dechucking system | United States of America | Granted | 2002-04-23 | 2000-10-24 | 6376795 | 09695534 |
| Modular growth of multiple gate oxides | United States of America | Granted | 2004-11-02 | 2002-12-31 | 6812158 | 10335177 |
| Key hole filling | United States of America | Granted | 2003-11-11 | 2002-07-22 | 6645857 | 10201010 |
| Bond pad design | United States of America | Lapsed | 2006-04-04 | 2003-01-13 | 7023067 | 10341082 |
| Method of Electrically Connecting and Isolating Components With Vertical Elements Extending Between Interconnect Layers in an Integrated Circuit. | United States of America | Abandoned | | 1998-03-31 | | 09052793 |
| Integrated process tool monitoring system for semiconductor fabrication | United States of America | Granted | 2003-11-18 | 2002-10-30 | 6650958 | 10283688 |
| Feed forward leveling | United States of America | Lapsed | 2004-11-16 | 2002-11-15 | 6818365 | 10295489 |
| Method and apparatus for monitoring the condition of a lubricating medium | United States of America | Granted | 2005-03-22 | 2002-11-13 | 6870160 | 10293631 |
| Chromeless phase shift mask using non-linear optical materials | United States of America | Lapsed | 2005-03-08 | 2002-12-24 | 6864020 | 10328346 |
| Metal-Oxide-Semiconductor Device Having An Ennanced Snielding Structure | of) | Lapsed | 2010-02-18 | 2005-08-16 | 102005038998.8 | 1020050389988 |
| | . | | | | | |
| FORMATION OF IMPROVED LOW DIELECTRIC CONSTANT CARBON-CONTAINING SILICON OXIDE DIELECTRIC MATERIAL BY REACTION OF CARBON-CONTAINING SILANE WITH OXIDIZING AGENT IN THE PRESENCE OF ONE OR MORE REACTION RETARDANTS | United States of America | Granted | 2003-02-25 | 1999-03-22 | 6524974 | 09274254 |
| Method for the formation of active area utilizing reverse trench isolation | United States of America | Granted | 2004-06-01 | 2002-12-20 | 6743701 | 10324698 |
| Thin Film Transistors | Japan | Granted | 2012-10-05 | 2000-11-29 | 5099942 | 2000362320 |
| Vertical Replacement Gate (VRG) MOSFET With A Conductive Layer Adjacent A Source/Drain Region And Method Of Manufacture Therefor | Japan | Lapsed | 2009-10-30 | 2001-03-06 | 4397537 | 2001061239 |
| Method For Producing Piezoelectric Films With Rotating Magnetron Sputtering System | Japan | Lapsed | 2012-09-28 | 2001-02-09 | 5093943 | 200133034 |
| Semiconductor Device Having Self-Aligned Contact And Landing PAD Structure And Method Of Forming Same | Japan | Lapsed | 2011-09-16 | 2000-11-29 | 4820978 | 2000362265 |
| Metal-Oxide Semiconductor Device Having Improved Performance And Reliability. | Japan | Lapsed | 2013-08-09 | 2004-10-15 | 5334351 | 2004300894 |
| Selective Isotropic Etch For Titanium Based Materials | Japan | Granted | 2011-11-04 | 2004-09-27 | 4855665 | 2004278932 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method For Producing Devices Having Piezoelectric Films | of) | Granted | 2010-12-22 | 2001-01-29 | 60143682.2 | 013007406 |
|--|----------------------------|----------|------------|------------|------------|-------------------------------|
| | Germany (Federal Republic | | | | | |
| Engineering database feedback system | United States of America | Granted | 2002-12-24 | 2000-06-20 | 6499001 | 09596909 |
| Thermal characterization compensation | United States of America | Granted | 2003-10-28 | 2002-02-15 | 6638776 | 10077497 |
| Simplified High Q Inductor Substrate | of) | Granted | 2008-01-02 | 1999-11-02 | 69937868.0 | 993087006 |
| | Germany (Federal Republic | | | | | |
| Fabricating High-Q RF Component | of) | Lapsed | 2005-02-16 | 2000-02-28 | 60018121.9 | 003015302 |
| | Germany (Federal Republic | | | | | |
| Integrated Circuit Device Having Dual Damascene Capacitor | of) | Granted | 2012-04-18 | 2000-01-06 | 60047099.7 | 003000528 |
| | Germany (Federal Republic | | | | | |
| Formed | of) | Expired | 2003-08-27 | 1997-03-25 | 69724317.6 | 973020498 |
| Process For Device Fabrication In Which A Thin Layer Of Cobalt Silicide Is | Germany (Federal Republic | | | | | |
| An Inductor Or Low Loss Interconnect In An Integrated Circuit | of) | Granted | 2007-05-30 | 1999-10-25 | 69936175.3 | 993084235 |
| Germany (Federal Republic An Inductor Or Low Loss Interconnect And A Method Of Manufacturing | Germany (Federal Republic | | | | | |
| Method For Forming Vias in a Low Dielectric Constant Material | of) | Lapsed | 2008-03-26 | 2000-10-16 | 60038423.3 | 003090859 |
| | Germany (Federal Republic | | | | | |
| Method of Manufacturing An Integrated Circuit | of) | Lapsed | 2006-07-26 | 2001-08-17 | 60121685.7 | 013070107 |
| | Germany (Federal Republic | | | | | |
| Fabricating Article | of) | Lapsed | 2001-04-11 | 1999-03-02 | 69900076.9 | 993015569 |
| Article Commission Filterinated Diamond Libe Carbon And Mathod For | Company (Todoral Postiblio | Glaillen | 2000-07-23 | 2000-03-03 | O'TCCECOOD | 100/0000 |
| Electron Emitters for Lithography Tools | Germany (Federal Republic |) | 7000 07 77 | 70000 | 00000 | 000000000 |
| A Capacitor For Integration With Copper Damascene Processes | OT) | Granted | 2010-08-25 | 2001-01-08 | 60142863.3 | 013001250 |
| | Germany (Federal Republic | | | | | |
| Lens Array For Electron Beam Lithography Tool | of) | Lapsed | 2012-11-21 | 2000-10-03 | 60047649.9 | 003086857 |
| | Germany (Federal Republic | | | | | |
| material | United States of America | Granted | 2003-05-20 | 2002-05-03 | 6566244 | 10138609 |
| Process for improving mechanical strength of layers of low k dielectric | | | | | | |
| Method And Apparatus For Imaging Semiconductor Devices | of) | Granted | 2005-07-27 | 1998-05-05 | 69830946.4 | 983035007 |
| | Germany (Federal Republic | | | | | |
| Same | of) | Lapsed | 2004-08-04 | 1998-09-08 | 69825384.1 | 983072323 |
| Dielectric Materials Of Amorphous Compositions And Devices Employing | Germany (Federal Republic | | | | | |
| Process For Fabricating Bipolar And BICMOS Devices | of) | Lapsed | 2000-11-15 | 1999-03-02 | 69900028.9 | 993015437 |
| | Germany (Federal Republic | | | | | |
| Thermor | of) | Lapsed | 2011-10-12 | 2000-03-28 | 60046543.8 | 003025376 |
| Method For Processing Silicon Workpieces Using Hybrid Optical | Germany (Federal Republic | | | | | |
| Plasma passivation | United States of America | Lapsed | 2004-10-19 | 2002-07-08 | 8806038 | 10190954 |
| | | | | | | ***************************** |

| Process For Producing Multi\(miLevel Metallization In An Integrated Circuit | United States of America | Expired | 1999-09-21 | 1997-03-27 | 5956618 | 08828155 |
|--|--------------------------|-----------|------------|------------|------------|-------------|
| Method For Producing Piezoelectric Films With Rotating Magnetron Sputtering System | Korea, Republic of (KR) | Lapsed | 2009-03-16 | 2001-02-09 | 10-0890080 | 20070073750 |
| A Spiral Inductor Formed In A Semiconductor Substrate And A Method For Forming The Inductor | Japan | Abandoned | | 2004-08-20 | | 2007210590 |
| Bonded Article Having Improved Crystalline Structure And Work Function Uniformity And Method For Making The Same | Japan | Lapsed | 2013-10-25 | 2000-06-21 | 5392995 | 2007130041 |
| A Method of Testing an Integrated Circuit | Japan | Lapsed | 2012-06-15 | 2001-06-27 | 5011459 | 2007063290 |
| Article Comprising An Organic Thin Film Transistor | United States of America | Expired | 1997-01-21 | 1996-05-10 | 5596208 | 08644596 |
| Copper Silicide Passivation For Improved Reliability | United States of America | Granted | 2005-03-22 | 2003-06-30 | 6869873 | 10609889 |
| Bipolar Tranistor Having A Low K Material In The Emitter Region | Japan | Granted | 2015-01-09 | 2001-08-03 | 5676836 | 2007187885 |
| Article Comprising A Variable Inductor | Japan | Lapsed | 2011-08-12 | 2006-12-28 | 4797199 | 2006353600 |
| Cross-Fill Pattern For Metal Fill Levels, Power-Supply Filtering, And Analog Circuit Shielding | United States of America | Granted | 2008-03-11 | 2006-01-26 | 7342316 | 11339540 |
| Energy-Sensitive Resist Material And A Process For Device Fabrication Using An Energy-Sensitive Resist Material | United States of America | Expired | 1997-08-12 | 1995-11-03 | 5656412 | 08552998 |
| Process For Controlled Deprotection Of Polymers And A Process For Fabricating A Device Utilizing Partially Deprotected Resist Polymers | United States of America | Expired | 1997-11-25 | 1994-07-20 | 5691110 | 08277852 |
| In situ measurement | United States of America | Granted | 2003-06-03 | 2002-03-25 | 6574525 | 10105483 |
| Selective Laser Annealing Of Semiconductor Material | United States of America | Lapsed | 2009-10-20 | 2006-05-22 | 7605064 | 11438493 |
| Liquid based air filtration system | United States of America | Granted | 2003-11-04 | 2001-09-19 | 6641635 | 09957555 |
| Process for treating porous low k dielectric material in damascene structure to form a non-porous dielectric diffusion barrier on etched via and trench surfaces in the porous low k dielectric material | United States of America | Granted | 2003-03-25 | 2001-12-04 | 6537896 | 10007405 |
| Process for forming low K dielectric material between metal lines | United States of America | Granted | 2002-07-23 | 2000-10-31 | 6423630 | 09704164 |
| Integrated Circuit Isolation System | United States of America | Abandoned | | 2000-09-05 | | 09654689 |
| Photolithography overlay control | United States of America | Granted | 2002-10-29 | 2001-10-04 | 6472316 | 09971329 |
| Cleanliness verification system | United States of America | Granted | 2002-07-02 | 2000-08-15 | 6412358 | 09639449 |
| Composite low dielectric constant film for integrated circuit structure | United States of America | Granted | 2002-12-10 | 2000-06-27 | 6492731 | 09605380 |
| Vortex unit for providing a desired environment for a semiconductor process | United States of America | Granted | 2004-06-15 | 2001-10-17 | 6750668 | 09981200 |
| Conditioning bar assembly having an abrasion member supported on a polycarbonate member | United States of America | Granted | 0 | 2002-08-20 | 6764389 | 10224025 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method and apparatus for estimating state-dependent gate leakage in an integrated circuit | United States of America | Granted | 2004-04-06 | 2001-09-17 | 6718524 | 09953667 |
|--|--------------------------|-----------|------------|------------|----------|------------|
| Integrated circuit device having a capacitor with the dielectric peripheral region being greater than the dielectric central region | United States of America | Expired | 2000-09-05 | 1996-06-28 | 6115233 | 08673655 |
| Process for removing resist mask of integrated circuit structure which mitigates damage to underlying low dielectric constant silicon oxide dielectric layer | United States of America | Granted | 2001-11-13 | 1999-10-26 | 6316354 | 09428344 |
| Test limits based on position | United States of America | Granted | 2003-07-22 | 2000-08-18 | 6598194 | 09641661 |
| Integrated circuit device and method of making the same using chemical mechanical polishing to remove material in two layers following masking | United States of America | Expired | 2001-09-04 | 1999-11-01 | 6284586 | 09431439 |
| Process for reducing defects in copper-filled vias and/or trenches formed in porous low-k dielectric material | United States of America | Granted | 2004-04-20 | 2001-08-17 | 6723653 | 09932527 |
| Vacuum valve interface | United States of America | Granted | 2001-05-01 | 1999-09-29 | 6223770 | 09407357 |
| Reactor system | United States of America | Granted | 2008-01-01 | 2001-12-10 | 7314527 | 10012821 |
| Process control system | United States of America | Granted | 2003-01-28 | 2000-05-19 | 6512985 | 09574365 |
| structure | United States of America | Granted | 2002-04-09 | 2000-06-28 | 6368979 | 09607511 |
| Process for forming trenches and vias in layers of low dielectric constant carbon-doped silicon oxide dielectric material of an integrated circuit | | | | | | |
| Self-Aligned Alignment Marks For Phase-Shifting Masks | United States of America | Expired | 1997-05-27 | 1995-07-11 | 5633103 | 08500729 |
| Article Comprising An Organic Thin Film Transistor Adapted For Biasing To Form A N-Type Or A P-Type Transistor | United States of America | Granted | 2001-08-21 | 1995-05-15 | 6278127 | 08441142 |
| Semiconductor Device Fabrication | United States of America | Expired | 1999-06-01 | 1997-05-28 | 5908312 | 08864220 |
| Dielectric Materials | United States of America | Expired | 1999-07-13 | 1998-03-12 | 5923056 | 09041434 |
| Electronic Components With Doped Metal Oxide Dielectric Materials And A Process For Making Electronic Components With Doped Metal Oxide | | | | | | |
| An Article For De-Embedding Parasitics In Integrated Circuits | United States of America | Granted | 2001-04-03 | 1999-02-02 | 6211541 | 09241458 |
| Thin-Film Transistor Monolithically Integrated With An Organic Light- Emitting Diode | United States of America | Granted | 2000-11-21 | 1999-09-08 | 6150668 | 09391729 |
| Capacitance | United States of America | Granted | 2007-11-27 | 2003-10-27 | 7301107 | 10694611 |
| Semiconductor Device Having Reduced Intra-Level And Inter-Level | | | | | | |
| Method of Doping a Semiconductor Surface | United States of America | Expired | 2001-05-08 | 1997-12-30 | 6228750 | 09000930 |
| Semiconductor Device | United States of America | Granted | 2006-06-27 | 2003-11-25 | 7067419 | 10721126 |
| Mask Layer And Dual Damascene Interconnect Structure In A | | | | | | |
| A Capacitor For Integration With Copper Damascene Processes | neder | Abandoned | | 2007-04-12 | | 2007104568 |
| PMOSFETs Having Indium Or Gallium Doped Buried Channels And N\(pl PolysiliconGates And CMOS Devices Fabricated Therefrom | United States of America | Expired | 1998-06-16 | 1996-05-24 | 5767557 | 08656996 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Process for Fabricating a Device | United States of America | Expired | 1998-05-12 | 1994-05-02 | 5750312 | 08236706 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Intermittent pulsed oxidation process | United States of America | Granted | 2003-11-18 | 2001-11-19 | 6649537 | 10044215 |
| Use of MEV implantation to form vertically modulated N+ buried layer in an NPN bipolar transistor | United States of America | Expired | 1999-01-12 | 1997-02-18 | 5858828 | 08801668 |
| Process for depositing titanium nitride films | United States of America | Granted | 2000-06-06 | 1998-05-07 | 6071562 | 09074298 |
| Polishing Composition for CMP Operations | Japan | Expired | 2000-10-20 | 1996-12-25 | 3121274 | 08344898 |
| Apparatus and method for blocking the deposition of oxide on a wafer | United States of America | Granted | 2000-09-19 | 1998-12-03 | 6120607 | 09204813 |
| Polishing composition for CMP operations | United States of America | Expired | 1999-01-19 | 1997-03-20 | 5861055 | 08822078 |
| Method of Electrically Connecting and Isolating Components with Vertical Elements Extending Between Interconnect Layers in an Integrated Circuit | United States of America | Abandoned | | 1900-01-01 | | 09052793 |
| Method and arrangement for fabricating a semiconductor device | United States of America | Granted | 2000-10-24 | 1999-04-30 | 6136719 | 09302830 |
| Alignment process for integrated circuit structures on semiconductor substrate using scatterometry measurements of latent images in spaced apart test fields on substrate | United States of America | Lapsed | 2004-10-26 | 2001-11-30 | 6809824 | 10006398 |
| Interconnect-integrated metal-insulator-metal capacitor and method of fabricating same | United States of America | Granted | 2002-01-29 | 2000-04-27 | 6342734 | 09559934 |
| Mobile ionic contamination detection in manufacture of semiconductor devices | United States of America | Granted | 2002-02-19 | 1999-06-25 | 6348808 | 09344056 |
| Apparatus and method of detecting a polishing endpoint layer of a semiconductor wafer which includes a metallic reporting substance | United States of America | Granted | 2000-09-19 | 1998-12-11 | 6121147 | 09209704 |
| Method and apparatus for detecting a polishing endpoint based upon heat conducted through a semiconductor wafer | United States of America | Granted | 2000-06-20 | 1998-06-30 | 6077783 | 09109335 |
| MeV implantation to form vertically modulated N+ buried layer in an NPN bipolar transistor | United States of America | Expired | 2001-11-13 | 1998-12-14 | 6316817 | 09272732 |
| Chemical mechanical polishing pad | United States of America | Granted | 2003-11-18 | 2001-09-05 | 6648743 | 09946253 |
| Capacitor with multiple-component dielectric and method of fabricating same | United States of America | Granted | 2002-01-22 | 2000-05-17 | 6341056 | 09573123 |
| Process to prevent stress cracking of dielectric films on semiconductor wafers | United States of America | Granted | 2001-05-15 | 1999-06-30 | 6232658 | 09346493 |
| Subtractive oxidation method of fabricating a short-length and vertically-oriented channel, dual-gate, CMOS FET | United States of America | Granted | 2002-03-12 | 1999-10-06 | 6355532 | 09413667 |
| Method and apparatus for enhancing uniformity during polishing of a semiconductor wafer | United States of America | Granted | 2002-04-23 | 2000-06-05 | 6375550 | 09587609 |
| Process for forming trenches and vias in layers of low dielectric constant carbon-doped silicon oxide dielectric material of an integrated circuit structure | United States of America | Granted | 2002-02-26 | 2000-06-28 | 6350700 | 09607512 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
| | | | | | | |

| Dielectric Deposition Method and Semiconductor Device | United States of America | Granted | 2003-01-14 | 2000-04-25 | 6506690 | 09557430 |
|--|--------------------------|-----------|------------|------------|----------|------------------|
| | United States of America | Granted | 2004-09-21 | 2000-12-21 | 6794694 | |
| Method And Apparatus For Determining Yield Impacting Tests At Wafer Level And Package Level For Semiconductor Devices | United States of America | Granted | 2002-09-03 | 2000-05-31 | 6445206 | 09583936 |
| A Method For Fabricating A Thin-Film Transistor | United States of America | Granted | 2001-12-11 | 2000-06-01 | 6329226 | 09585159 |
| Bipolar Transistor Having An Isolation Structure Located Under The Base, Emitter And Collector And A Method Of Manufacture Thereof | United States of America | Lapsed | 2005-02-08 | 2000-08-11 | 6853048 | 09637496 |
| Conditioning Wheel For Conditioning A Semiconductor Wafer Polishing Pad And Method Of Manufacture Thereof | United States of America | Granted | 2004-03-09 | 2001-02-07 | 6702654 | 09778986 |
| An Alternate Pad Conditioning Method | United States of America | Abandoned | | 2001-02-06 | | 09777470 |
| Method Of Manufacturing A Polishing Pad Using A Beam | United States of America | Granted | 2002-10-08 | 2001-02-16 | 6462305 | 09785636 |
| Method Of Manufacturing A Channel Stop Implant In A Semiconductor Device | United States of America | Granted | 2002-10-29 | 2001-11-05 | 6472279 | 09993414 |
| Stress Migration Test Structure And Method Therefor | United States of America | Granted | 2004-06-08 | 2001-10-31 | 6747445 | 10007904 |
| Integrated Circuit Having Stress Migration Test Structure And Method Therefor | United States of America | Granted | 2004-01-27 | 2001-10-31 | 6683465 | 10007417 |
| Temperature Optimization Of A Physical Vapor Deposition Process To Prevent Extrusion Into Openings | United States of America | Granted | 2006-04-25 | 2003-08-01 | 7033931 | 10633334 7033931 |
| Three-Terminal Tuneable Active Inductor | United States of America | Granted | 2007-04-03 | 2004-08-30 | 7199685 | 10929843 |
| Method and Apparatus Using An On-Chip Ring Oscillator For Chip Identification | United States of America | Granted | 2005-05-17 | 2003-08-18 | 6893883 | 10643123 |
| Shielding Structure For Use In A Metal\(miOxide\(miSemiconductor)) Device | United States of America | Granted | 2006-11-21 | 2003-07-21 | 7138690 | 10623983 |
| Test Structure And Method For Yield Improvement Of Double Poly Bipolar Device | United States of America | Lapsed | 2006-07-11 | 2004-09-22 | 7074628 | 10947069 |
| Base Current Compensation Circuit For A Bipolar Junction Transistor | United States of America | Lapsed | 2006-10-03 | 2004-09-29 | 7116174 | 10953897 |
| Control Of Hot Carrier Injection In A Metal-Oxide Semiconductor Device | United States of America | Granted | 2007-10-09 | 2004-10-29 | 7279744 | 10977732 |
| Control Of Hot Carrier Injection In A Metal-Oxide Semiconductor Device | United States of America | Lapsed | 2010-10-26 | 2007-09-11 | 7820517 | 11853417 |
| Calibration Standard For Transmission Electron Microscopy | United States of America | Granted | 2007-11-06 | 2005-09-28 | 7291849 | 11237410 |
| Embedded Test Circuitry And A Method For Testing A Semiconductor Device For Breakdown, Wearout Or Failure | United States of America | Granted | 2008-02-19 | 2005-11-15 | 7332924 | 11273857 |
| Fill Patterning For Symmetrical Circuits | United States of America | Granted | 2013-04-16 | 2008-12-19 | 8423942 | 12339407 |
| Method of manufacturing a semiconductor device having PN junctions separated by depressions | United States of America | Expired | 1997-08-26 | 1995-06-06 | 5661091 | 08479018 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method To Reduce Collector Resistance Of A Vertical PNP And Integration Into A Standard CMOS Process Flow | Japan | Lapsed | 2012-09-14 | 2007-02-14 | 5084843 | 2009549571 |
|---|--------------------------|-----------|------------|------------|----------|------------|
| Chip Identification Using Top Metal Layer | United States of America | Granted | 2012-08-14 | 2010-07-08 | 8242603 | 12741839 |
| Chip Identification Using Top Metal Layer | European Patent | Abandoned | | 2007-12-10 | | 078690823 |
| Mitigation of Detrimental Breakdown of a High Dielectric Constant Metal- Insulator-Metal Capacitor in a Capacitor Bank | United States of America | Granted | 2014-01-07 | 2010-11-24 | 8624352 | 12953624 |
| Process For Patterning Conductive Polyaniline Films | United States of America | Granted | 2000-04-04 | 1998-02-19 | 6045977 | 09026227 |
| Field Emission Device And Method For Making Same | United States of America | Expired | 1996-12-31 | 1995-10-26 | 5588894 | 08548533 |
| Field Emission Device With Randomly Distributed Gate Apertures | United States of America | Expired | 1997-12-16 | 1996-08-12 | 5698934 | 08695441 |
| System And Method For Determining Near-Surface Lifetimes And The Tunneling Field Of A Dielectric In A Semiconductor | United States of America | Expired | 2000-01-04 | 1997-07-03 | 6011404 | 08887861 |
| Minimal Delay Conductive Lead Lines For Integrated Circuits | United States of America | Expired | 1998-11-24 | 1996-11-26 | 5841333 | 08756695 |
| Manufacturing Method Including Near-Field Optical Microscope Examination OfA Semiconductor Substrate | United States of America | Expired | 1999-04-13 | 1997-08-20 | 5894349 | 08919192 |
| Method Of Reducing Mobile Ion Contaminants In Semiconductor Films | United States of America | Granted | 2000-01-25 | 1998-01-26 | 6017805 | 09013486 |
| Passivated Copper Surfaces | United States of America | Granted | 2001-11-27 | 1998-06-13 | 6323131 | 09096998 |
| Electrodeposition Apparatus For Coating Wafers | United States of America | Granted | 1999-11-02 | 1998-04-30 | 5976331 | 09070387 |
| On-Chip Capacitor Structure | United States of America | Granted | 2000-03-14 | 1998-07-29 | 6037621 | 09126032 |
| A Method for Forming a Nitride Layer Suitable for Use in Advanced Gate Dielectric Materials | United States of America | Granted | 2001-01-23 | 1998-09-29 | 6177363 | 09162542 |
| Low Temperature Coefficient Dielectric Materials And Devices Comprising Same | United States of America | Granted | 2000-07-25 | 1998-12-29 | 6093668 | 09222110 |
| N\(miProfile Engineering At The Poly\(slGate Oxide And Gate Oxide\(slSl Interfaces Through ! NH sub 3 !, Annealing Of A Layered Poly\(slá\\miSi Structure | United States of America | Granted | 2002-08-27 | 1998-12-30 | 6440829 | 09223354 |
| Digital Noise Reduction In Integrated Circuits And Circuit Assemblies | United States of America | Granted | 2000-09-19 | 1999-04-15 | 6121827 | 09293510 |
| Method Of Making Devices Having Thin Dielectric Layers | United States of America | Granted | 2001-09-25 | 1999-07-12 | 6294447 | 09351971 |
| Article Comprising Electronic Circuits And Devices With Magnetically Programmable Electrical Resistance | United States of America | Granted | 2001-05-01 | 1999-01-14 | 6225801 | 09231566 |
| Predictive Probe Stabilization Relative To subject Movement | United States of America | Granted | 2002-04-02 | 1999-12-23 | 6366803 | 09470861 |
| Interferometric Probe Stabilization Relative To Subject Movement | United States of America | Granted | 2004-01-20 | 1999-12-23 | 6680780 | 09472326 |
| Using Fast Hot-Carrier Aging Method For Measuring Plasma Charging Damage | United States of America | Granted | 2003-02-25 | 1999-05-24 | 6524872 | 09317430 |
| CMP System And Slurry For Polishing Semiconductor Wafers And Related Method | United States of America | Granted | 2002-04-02 | 2000-02-02 | 6364744 | 09496829 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method for Controlling Trench Depth In Shallow Trench Isolation Features | United States of America | Lapsed | 2006-08-08 | 2003-09-30 | 7087498 | 10675259 |
|---|--------------------------|-----------|------------|------------|------------------|---------------|
| A Semiconductor Device And A Method Of Manufacture Therefor | United States of America | Lapsed | 2010-10-12 | 2005-06-27 | 7811944 | 11167772 |
| A Semiconductor Device And A Method Of Manufacture Therefor | United States of America | Lapsed | 2006-02-28 | 2004-02-13 | 7005724 | 10778454 |
| A Semiconductor Device Having A Dummy Conductive Via And A Method Of Manufacture Therefor | United States of America | Granted | 2007-01-02 | 2004-05-10 | 7157365 | 10842139 |
| Method To Improve Writer Leakage in SiGe Bipolar Device | United States of America | Granted | 2011-03-01 | 2009-06-02 | 7898038 | 12476994 |
| Method To Improve Writer Leakage in a SiGe Bipolar Device | United States of America | Granted | 2009-07-07 | 2007-02-12 | 7557010 | 11673645 |
| Capacitance Density | United States of America | Granted | 2010-08-03 | 2004-07-30 | 7768044 | 10903938 |
| Metal Capacitor Stacked With A MOS Capacitor To Provide Increased | | | | | | |
| Semiconductor Structure Formed Using A Sacrificial Structure | United States of America | Granted | 2010-06-22 | 2007-10-30 | 7741702 | 11927978 |
| Semiconductor Structure Formed Using A Sacrificial Structure | United States of America | Granted | 2008-02-12 | 2005-03-31 | 7329605 | 11094975 |
| Metallization Levels | United States of America | Lapsed | 2010-06-01 | 2007-01-03 | 7727894 | 11649015 |
| A Trench Isolation Structure And Method Of Manufacture Therefor | United States of America | Granted | 2007-10-09 | 2004-09-29 | 7279393 | 10953632 |
| Integrated Circuit Inductors With Reduced Magnetic Coupling | ┖ | Granted | 2012-03-27 | 2009-05-26 | 8143696 | 12516301 |
| Wagnetic Coupling Reduction | | Abandoned | | 2010-12-13 | | 2012500769 |
| Integrated Circuit Inductors With Directed Magnetic Flux Lines For | | | | | | |
| Integrated Circuit Inductors With Directed Magnetic Flux Lines For Magnetic Coupling Reduction | China | Lapsed | 2014-03-19 | 2009-03-18 | ZL200980122262.2 | 2009801222622 |
| Magnetic Coupling Reduction | Taiwan | Lapsed | 2013-04-21 | 2009-07-02 | 1394180 | 098122453 |
| Integrated Circuit Inductors With Directed Magnetic Flux Lines For | | | | | | |
| Integrated Circuit Inductors With Directed Magnetic Flux Lines For Magnetic Coupling Reduction | Korea, Republic of (KR) | Granted | 2015-12-01 | 2009-03-18 | 101575387 | 20107028513 |
| Magnetic Coupling Reduction | European Patent | Abandoned | | 2009-03-18 | | 097895247 |
| Integrated Directit Indicators With Directed Magnetic Files Linger For | | | | | | |
| Shallow Trench Isolation Structures Comprising A Graded Doped Sacrificial Silicon Dioxide Material And A Method For Forming Shallow Trench Isolation Structures | United States of America | Granted | 2006-11-28 | 2005-06-15 | 7141486 | 11153893 |
| Manufacture | United States of America | Lapsed | 2009-07-21 | 2006-05-16 | 7563669 | 11383670 |
| Integrated Circuit With A Trench Capacitor Structure And Method Of | | | | | | |
| Integrated Circuit With Depletion Mode JFET | United States of America | Lapsed | 2010-01-05 | 2005-09-28 | 7642617 | 11237095 |
| Differential Inductor For Use In Integrated Circuits | United States of America | Granted | 2010-12-07 | 2006-09-27 | 7847666 | 11535501 |
| Integration Into A Standard CMOS Flow | United States of America | Granted | 2011-04-12 | 2009-07-16 | 7923340 | 12523368 |
| | - | 5 | 100 | | | |
| Method To Reduce Collector Resistance Of A Bipolar Transistor and Integration into a CMOS Flow | Korea, Republic of (KR) | Lapsed | 2013-10-14 | 2007-02-14 | 10-1320913 | 1020097019023 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
| | | | | | | |

| A Method Of Forming A High Quality Gate Oxide Layer Having A Uniform Thickness | United States of America | Granted | 2003-04-08 | 2000-10-12 | 6544907 | 09689030 |
|---|--------------------------|---------|------------|------------|------------|---------------|
| Method And Structure For Modular, Highly Linear MOS Capacitors Using Nitrogen Implantation | United States of America | Granted | 2004-07-20 | 2001-09-26 | 6764930 | 09964227 |
| Method Of Fabricating Complementary Self-Aligned Bipolar Transistors | United States of America | Granted | 2004-07-27 | 2002-02-01 | 6767797 | 10061475 |
| Method And Structure For Oxide/Silicon Nitride Interface Substructure Improvements | Taiwan | Granted | 2003-11-11 | 2002-09-27 | NI-190044 | 091122325 |
| Method And Structure For Oxide/Silicon Nitride Interface Substructure Improvements | Korea, Republic of (KR) | Granted | 2008-11-17 | 2002-09-27 | 10-0869913 | 1020020058733 |
| Method And Structure For Oxide/Silicon Nitride Interface Substructure Improvements | United Kingdom | Lapsed | 2006-03-29 | 2002-09-26 | 2383686 | 02223899 |
| Method And Structure For Oxide/Silicon Nitride Interface Substructure Improvements | United States of America | Granted | 2003-04-15 | 2001-09-27 | 6548422 | 09966779 |
| Methods And Apparatus For The Detection Of Damaged Regions On Dielectric Film Or Other Portions Of A Die | United States of America | Lapsed | 2005-07-19 | 2003-10-31 | 6919228 | 10699021 |
| Semiconductor Resistor | United States of America | Lapsed | 2006-04-25 | 2004-01-30 | 7034653 | 10768771 |
| Methods Of Downstream Microwave Photoresist Removal And Via Clean, Particularly Following Stop-On TiN Etching | United States of America | Granted | 2007-01-02 | 2004-08-25 | 7157375 | 10925555 |
| Chemical Mechanical Polishing Pad With Grooves Alternating Between A Larger Groove Size And A Smaller Groove Size | United States of America | Lapsed | 2005-10-04 | 2004-03-12 | 6951510 | 10799279 |
| Operation Of Semiconductor Devices Subject To Hot Carrier Injection | United States of America | Lapsed | 2005-11-08 | 2004-07-26 | 6963215 | 10898792 |
| Electronic Fingerprinting Of Semiconductor Integrated Circuits | United States of America | Granted | 2004-05-18 | 2002-09-30 | 6738294 | 10262654 |
| Apparatus And Method For Detecting Alpha Particles | United States of America | Lapsed | 2004-12-07 | 2002-09-30 | 6828561 | 10260694 |
| Semiconductor Testing | United States of America | | 2006-08-01 | 2004-09-29 | 7084648 | 10953585 |
| Process For The Selective Control Of Feature Size In Lithographic Processing | United States of America | Lapsed | 2005-12-06 | 2003-05-12 | 6973637 | 10435870 |
| Diffused MOS Devices With Strained Silicon Portions And Methods For Forming Same | United States of America | Granted | 2004-12-07 | 2003-03-05 | 6828628 | 10382142 |
| Method And Apparatus For Cleaning Slurry Depositions From A Water Carrier | United States of America | Granted | 2007-02-06 | 2005-08-17 | 7172496 | 11205382 |
| Stringer Elimination In A BICMOS Process | United States of America | | 2010-04-20 | 2005-08-10 | 7700491 | 11201039 |
| Carrier Head For Chemical Mechanical Polishing | United States of America | Lapsed | 2006-04-25 | 2004-07-21 | 7033257 | 10895574 |
| Contact For Use In An Integrated Circuit And A Method Of Manufacture Therefor | United States of America | Lapsed | 2005-06-28 | 2003-11-18 | 6910907 | 10716299 |
| Reverse Conduction Protection Method And Apparatus For A Dual Power Supply Driver | United States of America | Granted | 2007-08-07 | 2003-11-12 | 7254002 | 10706467 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method Of Forming A Reverse Gate Structure With A Spin On Glass Process | United States of America | Granted | 2003-01-14 | 2001-06-11 | 6506673 | 09878690 |
|--|--------------------------|---------|------------|------------|------------|---------------|
| Polysilicon Bounded Snapback Device | Taiwan | Lapsed | 2006-05-11 | 2002-12-19 | 1255028 | 091136669 |
| Polysilicon Bounded Snapback Device | United States of America | Granted | 2003-03-18 | 2001-12-19 | 6534834 | 10024803 |
| Polysilicon Bounded Snapback Device | Japan | Lapsed | 2010-03-19 | 2002-12-19 | 4477298 | 2002368138 |
| Polysilicon Bounded Snapback Device | United Kingdom | Lapsed | 2005-09-28 | 2002-12-18 | 2387271 | 02294486 |
| Polysilicon Bounded Snapback Device | China | Granted | 2007-11-28 | 2002-12-19 | 02157198.8 | 021571988 |
| Polysilicon Bounded Snapback Device | Korea, Republic of (KR) | Granted | 2009-11-13 | 2002-12-18 | 10-927808 | 1020020081092 |
| Ferrite Film Formation Method And Apparatus | United States of America | Granted | 2004-04-06 | 2001-06-22 | 6716488 | 09887938 |
| Bipolar Device | United States of America | Granted | 2004-06-15 | 2001-01-23 | 6750528 | 09767477 |
| Method Of Dry Etching A Semiconductor Device In The Absence Of A Plasma | United States of America | Granted | 2004-05-04 | 2002-09-27 | 6730600 | 10259256 |
| A Method For Making A Merged Contact Window In A Transistor To Electrically Connect The Gate To Either The Source Or The Drain | United States of America | Granted | 2002-07-30 | 2000-08-11 | 6426263 | 09636447 |
| Device | United States of America | Lapsed | 2003-08-12 | 2001-05-11 | 6605529 | 09853317 |
| Process For Patterning A Membrane | United States of America | Granted | 2003-08-26 | 2001-05-24 | 6610464 | 09863437 |
| Split Barrier Layer Including Nitrogen-Containing Portion And Oxygen-Containing Portion | Taiwan | Granted | 2007-05-11 | 2002-12-06 | 1281224 | 091135431 |
| Split Barrier Layer Including Nitrogen-Containing Portion And Oxygen-Containing Portion | Japan | Granted | 2009-12-11 | 2002-12-26 | 4422403 | 2002376124 |
| Split Barrier Layer Including Nitrogen-Containing Portion And Oxygen-Containing Portion | United Kingdom | Lapsed | 2006-07-12 | 2002-12-03 | 2387027 | 02281962 |
| Split Barrier Layer Including Nitrogen-Containing Portion And Oxygen-Containing Portion | Korea, Republic of (KR) | Granted | 2007-09-12 | 2003-01-02 | 759721 | 1020030000063 |
| Split Barrier Layer Including Nitrogen-Containing Portion And Oxygen-Containing Portion | United Kingdom | Lapsed | 2006-09-13 | 2002-12-03 | 2422722 | 06003743 |
| Split Barrier Layer Including Nitrogen-Containing Portion And Oxygen-Containing Portion | United Kingdom | Lapsed | 2006-09-13 | 2002-12-03 | 2422721 | 06003727 |
| Split Barrier Layer Including Nitrogen-Containing Portion And Oxygen-Containing Portion | United States of America | Granted | 2005-04-12 | 2002-01-02 | 6879046 | 10038371 |
| Method Of Manufacturing An Interconnect Structure Having A Passivation Layer For Preventing Subsequent Processing Reactions | United States of America | Granted | 2002-08-13 | 2000-11-30 | 6432814 | 09727195 |
| Bipolar Transistor Having An Emitter Comprised Of A Semi-Insulating Material | United States of America | Granted | 2003-04-29 | 2002-01-17 | 6555852 | 10051937 |
| Method And Apparatus For Monitoring In-Line Copper Contamination | United States of America | Granted | 2003-08-19 | 2001-09-28 | 6607927 | 09968243 |
| Plated Through Hole Interconnections | United States of America | Granted | 2002-10-01 | 2001-04-11 | 6458696 | 09833251 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| GaAs MOSFET Having Low Capacitance and On\(miResistance And Method Of Manufacturing The Same | United States of America | Lapsed | 2004-01-27 | 2001-08-10 | 6682962 | 09927194 |
|--|--------------------------|---------|------------|------------|----------|-----------|
| GaAs MOSFET Having Low Capacitance and On-Resistance And Method Of Manufacturing The Same | France | Lapsed | 2008-12-31 | 2000-10-03 | 1091416 | 003086840 |
| GaAs MOSFET Having Low Capacitance and On-Resistance And Method Of Manufacturing The Same | United Kingdom | Lapsed | 2008-12-31 | 2000-10-03 | 1091416 | 003086840 |
| Methods For Deuterium Sintering | United States of America | Granted | 2003-06-10 | 2000-12-08 | 6576522 | 09733570 |
| Method of Manufacturing a Laterally Diffused Metal Oxide Semiconductor Device | United States of America | Granted | 2011-04-19 | 2009-09-08 | 7927940 | 12555082 |
| Semiconductor Device | United States of America | Granted | 2011-04-19 | 2001-01-04 | 7927939 | 09755826 |
| Bearing Substitute For Wafer Polishing Arm Mothod of Manufacturing a Literally Diffused Motal Oxide | United States of America | Granted | 2001-06-26 | 1999-10-15 | 6250991 | 09419453 |
| Method For Interconnecting Arrays Of Micromechanical Devices | United States of America | Granted | 2004-04-06 | 2000-05-26 | 6716657 | 09578894 |
| Calibration Method For Quantitative Elemental Analysis | United States of America | Granted | 2003-02-11 | 2000-05-09 | 6519543 | 09567359 |
| Method Of Testing An Unknown Sample With An Analytical Tool | United States of America | Granted | 2003-02-11 | 2000-05-09 | 6519542 | 09567373 |
| Wafer Polishing Apparatus And Process | United States of America | Granted | 2002-01-22 | 1999-10-15 | 6340327 | 09419259 |
| High Pressure Anneal For Semiconductor Devices | United States of America | Granted | 2001-08-14 | 2000-03-08 | 6274490 | 09521268 |
| Method For Treating An Effluent Gas During Semiconductor Processing | United States of America | Granted | 2002-10-29 | 2000-01-21 | 6471925 | 09488899 |
| Control Of Semiconductor Processing | United States of America | Granted | 2003-11-04 | 2001-09-28 | 6641746 | 09967435 |
| Novel Process For Gate Oxide Side-Wall Protection From Plasma Damage To Form Highly Reliable Gate Dielectrics | United States of America | Granted | 2002-11-05 | 2000-08-09 | 6475842 | 09634401 |
| Non-Contact Method For Determining Quality Of Semiconductor Dielectrics | United States of America | Granted | 2003-12-16 | 2001-01-08 | 6664800 | 09756965 |
| Mitigation Of Deleterious Effects Of Micropipes In Silicon Carbide Devices | United States of America | Granted | 2002-09-10 | 2000-08-08 | 6448581 | 09634021 |
| Slurry Recirculation System For Reduced Slurry Drying | United States of America | Granted | 2002-06-11 | 2000-05-03 | 6402599 | 09564659 |
| Semiconductor Device Having A Ghost Source/Drain Region And A Method Of Manufacture Therefor | United States of America | Lapsed | 2005-03-08 | 2001-06-15 | 6864547 | 09882911 |
| Electrochemical Method And System For Monitoring Hydrogen Peroxide Concentration In Slurries | United States of America | Lapsed | 2005-12-06 | 2002-09-27 | 6972083 | 10259254 |
| Slurry Container | United States of America | Granted | 2003-01-21 | 2000-03-31 | 6508363 | 09541792 |
| Device Having A High Dielectric Constant Material And A Method Of Manufacture Thereof | United States of America | Granted | 2003-01-28 | 2001-07-10 | 6511872 | 09902358 |
| A Method Of Focused Ion Beam Pattern Transfer Using A Smart Dynamic Template | United States of America | Granted | 2003-09-30 | 2000-08-03 | 6627885 | 09631545 |
| System And Method Of Determining A Polishing Endpoint By Monitoring Signal Intensity | United States of America | Granted | 2004-05-04 | 2001-10-25 | 6730603 | 10061542 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method For Regular Detection Of Phosphorus Striations In A Multi\(miLayered Film Stack | United States of America | Lapsed | 2003-07-15 | 2000-06-26 | 6593151 | 09604020 |
|--|-------------------------------|-----------|------------|------------|------------|------------|
| Method For Cleaning Via Openings In Integrated Circuit Manufacturing | United States of America | Granted | 2001-01-02 | 1999-03-25 | 6169036 | 09276034 |
| Manufacture Of Complementary MOS And Bipolar Integrated Circuits | United States of America | Granted | 2000-10-31 | 1999-08-27 | 6140170 | 09384769 |
| Bipolar Semiconductor Device And Method Of Forming Same Having Reduced Transient Enhanced Diffusion | United States of America | Granted | 2002-03-19 | 2000-02-15 | 6358807 | 09504306 |
| Polishing Apparatus With Carrier Ring And Carrier Head Employing Like Polarities | United States of America | Granted | 2002-03-12 | 2000-04-21 | 6354928 | 09553938 |
| Silicon Carbide Barrier Layers For Porous Low Dielectric Constant Materials | United States of America | Granted | 2002-06-25 | 2000-08-07 | 6410419 | 09633241 |
| Polishing Pads From Closed\(miCelled Elastomer Foam | United States of America | Granted | 2002-04-09 | 2000-03-02 | 6368200 | 09516836 |
| Apparatus For Chemical Mechanical Polishing Endpoint Detection Using A Hydrogen Sensor | United States of America | Granted | 2001-09-25 | 1999-10-14 | 6293847 | 09418087 |
| Method For Chemical Mechanical Polishing Endpoint Detection Using A Hydrogen Sensor | United States of America | Abandoned | | 1999-10-14 | | 09418078 |
| Semiconductor Device, Trench Isolation Structure And Methods Of Format Ion | United States of America | Granted | 2001-11-06 | 2000-06-07 | 6313007 | 09589816 |
| Mass Spectrometer Particle Counter | United States of America | Granted | 2003-10-14 | 2000-11-30 | 6633032 | 09727014 |
| Silicon Semiconductor Devices With ä-Doped Layers | United States of America | Granted | 2002-06-11 | 1999-10-29 | 6403454 | 09430316 |
| Dual Damascene Process With No Passing Metal Features | United States of America | Granted | 2006-01-24 | 2000-09-21 | 6989602 | 09667046 |
| Planar Movable Stage Mechanism | United States of America | Granted | 2001-12-04 | 1999-10-06 | 6324933 | 09413149 |
| A Method Of Deposition Of Films | United States of America | Granted | 2003-02-25 | 1999-12-17 | 6524971 | 09465633 |
| A Process For Improving Line Width Variations Between Tightly Spaced And Isolated Features In Integrated Circuits | United States of America | Granted | 2002-05-28 | 1999-09-16 | 6395639 | 09397458 |
| A Semicondutor Device Having Reduced Line Width Variations Between Tightly Spaced And Isolated Features | United States of America | Granted | 2002-06-18 | 1999-09-16 | 6406999 | 09397459 |
| GaAs MOSFET Having Low Capacitance and On-Resistance And Method Of Manufacturing The Same | Japan | Lapsed | 2010-07-30 | 2000-10-06 | 4558911 | 2000307041 |
| GaAs MOSFET Having Low Capacitance and On-Resistance And Method Of Manufacturing The Same | United States of America | Granted | 2002-04-09 | 1999-10-06 | 6369408 | 09412847 |
| Germany (Federal Republic GaAs MOSFET Having Low Capacitance and On-Resistance And Method of) Of Manufacturing The Same | Germany (Federal Republic of) | Lapsed | 2008-12-31 | 2000-10-03 | 60041233.4 | 003086840 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Device And In Situ Furnace Gate Stack Process For Metal Oxide Semiconductors | United States of America | Granted | 2000-10-31 | 1998-12-02 | 6140187 | 09205414 |
|---|--------------------------|-----------|------------|------------|----------|----------|
| Method Of Planarizing A Surface On A Semiconductor Wafer | United States of America | Granted | 2000-07-04 | 1998-05-20 | 6083838 | 09082162 |
| Polishing Apparatus With Carrier Head Pivoting Device | United States of America | Granted | 2000-05-02 | 1998-05-19 | 6056630 | 09081406 |
| Methods And Apparatus For Increasing Metal Density In An Integrated CircuitWhile Also Reducing Parasitic Capacitance | United States of America | Granted | 2000-08-01 | 1998-06-02 | 6097195 | 09088852 |
| Tungsten Silicide Nitride As A Barrier For High Temperature Anneals To Improve Hot Carrier Reliability | United States of America | Granted | 2002-04-02 | 1999-06-03 | 6365511 | 09324946 |
| Tungsten Silicide Nitride As A Barrier For High Temperature Anneals To Improve Hot Carrier Reliability | United States of America | Abandoned | | 1999-06-03 | | 09325624 |
| Metal Silicide As A Barrier For MOM Capacitors In CMOS Technologies | United States of America | Granted | 2002-01-01 | 1999-11-17 | 6335557 | 09441561 |
| A Method Of Fabricating A MOM Capacitor Having A Metal Silicide Barrier | United States of America | Granted | 2001-12-18 | 1999-11-17 | 6331460 | 09441676 |
| A Non-Contact Method For Monitoring And Controlling Plasma Charging Damage In A Semiconductor Device | United States of America | Granted | 2001-06-26 | 2000-10-06 | 6251697 | 09684015 |
| Method of Reducing Carbon Contamination of a Thin Dielectric Film by Using Gaseous Organic Precursors, Inert Gas, and Ozone to React with Carbon Contaminants | United States of America | Granted | 2000-09-26 | 1999-06-08 | 6124158 | 09327793 |
| Semiconductor Device Having Multilevel Interconnections And Method Of Manufacture Thereof | United States of America | Lapsed | 2004-01-27 | 1999-10-22 | 6682999 | 09426124 |
| Location Of Defects Using Dye Penetration | United States of America | Granted | 2000-08-01 | 1999-07-15 | 6097484 | 09353860 |
| Detecting Trace Levels Of Copper | United States of America | Granted | 2000-11-14 | 1998-11-21 | 6146909 | 09197412 |
| Scanning Electron Microscope\{s Energy Dispersive Spectroscopy Sample Preparation Method And Sample Produced Thereby | United States of America | Granted | 2002-03-26 | 1999-06-22 | 6362475 | 09337966 |
| Method For Fabricating Bipolar Transistors | United States of America | Granted | 2002-09-03 | 1999-07-08 | 6444536 | 09349538 |
| Etch Endpoint Detection | United States of America | Granted | 2001-05-08 | 1998-10-14 | 6228277 | 09172456 |
| Method Of Making A Semiconductor With Copper Passivating Film | United States of America | Granted | 2000-09-05 | 1999-06-23 | 6114234 | 09338735 |
| Apparatus And Method For Removing A Polishing Pad From A Platen | United States of America | Granted | 2001-10-09 | 1999-08-03 | 6299519 | 09366362 |
| Chemical Mechanical Polishing Endpoint Apparatus Using Component Activity In Effluent Slurry | United States of America | Granted | 2001-07-10 | 1999-11-01 | 6258231 | 09432721 |
| Component Activity In Effluent Slurry | United States of America | Granted | 2001-04-10 | 1999-11-01 | 6214732 | 09431198 |
| Endpoint Detection By Monitoring | | | | | | |
| Chemical Mechanical Polishing | | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Semiconductor Structure For Thermal Shutdown Protection | United States of America | Expired | 2000-01-11 | 1997-03-18 | 6013934 | 08819828 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Process For Reducing Transient Diffusion Of Dopant Atoms | United States of America | Expired | 1997-09-23 | 1995-08-07 | 5670391 | 08511845 |
| Apparatus For Determining The Thermal Resistivity Of Electrically Insulating Crystalline Materials | United States of America | Expired | 1997-09-09 | 1995-07-31 | 5664884 | 08509267 |
| Method Of Manufacturing Semiconductor Devices Having Improved Polycide Integrity Through Introduction Of A Silicon Layer Within The Polycide Structure | United States of America | Expired | 2000-11-28 | 1997-01-07 | 6153452 | 08782010 |
| Linearization Of Resistance | United States of America | Expired | 2000-01-25 | 1997-01-02 | 6018272 | 08778123 |
| Substrate Isolation For Analog/Digital IC Chips | United States of America | Expired | 1998-08-11 | 1997-03-11 | 5793093 | 08814817 |
| Integrated Photosensing Device For Active Pixel Sensor Imagers | United States of America | Expired | 1999-10-19 | 1997-04-29 | 5969337 | 08846967 |
| High-Speed Double-Heterostructure Bipolar Transistor Devices | United States of America | Expired | 1997-04-29 | 1996-06-03 | 5625206 | 08657255 |
| Field-Effect Photo-Transistor | United States of America | Expired | 1999-08-17 | 1997-02-10 | 5939742 | 08798327 |
| Plasma Etch Endpoint Detection Process | United States of America | Expired | 1999-03-02 | 1997-07-22 | 5877407 | 08898261 |
| Method And Apparatus For Chemical-Mechanical Polishing Of Diamond | United States of America | Expired | 1998-05-05 | 1996-12-05 | 5746931 | 08760845 |
| Integrated Circuit Fabrication | United States of America | Expired | 1999-08-31 | 1997-06-09 | 5945355 | 08871383 |
| Mechanism For Changing A Probe Balance Beam In A Scanning Probe Microscope | United States of America | Expired | 1998-05-26 | 1997-02-27 | 5756887 | 08807310 |
| Method Of Forming Semiconductor Device With LDD Structures | United States of America | Granted | 2003-06-10 | 1998-04-07 | 6576521 | 09056555 |
| Article Comprising Magnetoresistive Material | United States of America | Expired | 1999-01-05 | 1997-06-05 | 5856008 | 08869944 |
| Improved Complementary Semiconductor Devices | United States of America | Granted | 2001-10-16 | 1998-04-29 | 6303961 | 09069215 |
| Process For Forming Device Comprising Metallized Magnetic Substrates | United States of America | Granted | 2000-11-28 | 1999-08-05 | 6153078 | 09369105 |
| InAlGaP Devices | United States of America | Expired | 1998-12-01 | 1997-06-03 | 5844261 | 08868269 |
| Method For Fabricating An Article Comprising A Ladder Siloxane Polymer AndResultant Article | United States of America | Expired | 2001-06-26 | 1999-07-11 | 6251486 | 09352674 |
| Integrated Circuit Processing | United States of America | Expired | 1999-12-21 | 1997-09-03 | 6004827 | 08922487 |
| Method for Controlled Implantation Of Elements Into The Surface Or Near Surface Of A Substrate | United States of America | Granted | 2000-09-19 | 1998-08-24 | 6121624 | 09138741 |
| Multi\(miLayered Titanium Nitride Barrier Structure | United States of America | Granted | 2002-06-25 | 1998-12-22 | 6410986 | 09218574 |
| Calibration Sample For Particle Analyzers And Method For Making Same | United States of America | Granted | 2000-06-13 | 1998-04-02 | 6073476 | 09053908 |
| Trilayer Lift-Off Process For Semiconductor Device Metalization | United States of America | Granted | 2000-12-05 | 1998-04-13 | 6156665 | 09059359 |
| Article Comprising Fluorinated Amorphous Carbon And Process For Fabricating Article | United States of America | Granted | 2000-11-21 | 1998-11-19 | 6149778 | 09196486 |
| Repairing Fractured Wafers In Semiconductor Manufacturing | United States of America | Granted | 1999-08-03 | 1998-02-24 | 5932379 | 09028966 |
| Integrated Circuit Device In Which Gate Oxide Thickness Is Selected To Control Plasma Damage During Device Fabrication | United States of America | Granted | 2000-06-13 | 1998-06-18 | 6075273 | 09099827 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
| | | | | | | |

| Integrated Circuit Etching | United States of America | Expired | 1997-03-04 | 1995-04-28 | 5607543 | 08431341 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Method For Making A Semiconductor Device Including Diffusion Control | United States of America | Expired | 1996-03-19 | 1994-08-09 | 5500391 | 08287989 |
| Integrated Circuit Fabrication | United States of America | Expired | 2001-01-02 | 1997-09-29 | 6168904 | 08939422 |
| Improved Latch-Up Immunity | United States of America | Expired | 1998-02-24 | 1995-03-02 | 5721445 | 08397346 |
| Semiconductor Device With Increased Parasitic Emitter Resistance And | | | | | | |
| Interferometrically Profiled Mounting Film | United States of America | Expired | 1999-02-02 | 1995-05-31 | 5866436 | 08454976 |
| Process Of Manufacturing An Integrated Circuit Having An | | | | | | |
| Photolithography | United States of America | Expired | 1997-06-03 | 1995-10-31 | 5636002 | 08550879 |
| Auxiliary Mask Features For Enhancing The Resolution Of | | | | | | |
| Apparatus And Method For Making Integrated Circuits | United States of America | Expired | 1997-12-23 | 1997-01-29 | 5700725 | 08789892 |
| a Plasma Etch Process | United States of America | Expired | 1997-08-05 | 1995-11-07 | 5654903 | 08553118 |
| A Method and Apparatus for Real Time Monitoring of Wafer Attributes in | | | | | | |
| Titanium Silicide Process | United States of America | Expired | 1997-11-11 | 1995-12-07 | 5686359 | 08569025 |
| segmented gratings | United States of America | Expired | 1997-01-21 | 1995-08-17 | 5596413 | 08516368 |
| Sub-Micron Through-the-Lens Positioning utilizing out of phase | | | | | | |
| Stress Migration Evaluation Method | United States of America | Expired | 1999-07-27 | 1997-08-27 | 5930587 | 08917955 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Powdered Metal Heat Sink With Increased Surface Area | United States of America | Abandoned | | 1996-05-24 | | 08653591 |
|---|-----------------------------|-----------|------------|------------|----------|----------|
| High contact density ball grid array package for flip-chips | United States of America | Expired | 1997-06-10 | 1995-10-04 | 5637920 | 08538631 |
| Method of mounting a flip-chip | United States of America | Expired | 1998-07-28 | 1997-01-03 | 5784780 | 08778909 |
| Microelectronic integrated circuit mounted on circuit board with solder column grid array interconnection, and method of fabricating the solder column grid array | United States of America | Expired | 1997-06-17 | 1996-01-31 | 5639696 | 08595022 |
| Microelectronioc Integrated Circuit Mounted On Circuit Board With Solder Column Grid Array Interconnection (As Amended) | United States of America | Abandoned | | 1997-02-28 | | 08810304 |
| Method of packaging an integrated circuit | United States of America | Expired | 1997-12-23 | 1996-05-15 | 5700723 | 08648350 |
| Integrated Circuit Package. | United States of America | Abandoned | | 1997-12-11 | | 08989098 |
| Flip chip bump distribution on die | United States of America | Expired | 1999-09-14 | 1996-11-12 | 5952726 | 08747325 |
| Method for distributing connection pads on a semiconductor die | United States of America | Expired | 1999-03-23 | 1997-08-14 | 5885855 | 08909312 |
| Microelectronic package with polymer ESD protection | United States of America | Expired | 1999-09-21 | 1996-10-01 | 5955762 | 08723140 |
| Microelectronic device with thin film electrostatic discharge protection structure | United States of America | Expired | 1999-02-09 | 1996-01-31 | 5869869 | 08595021 |
| Method of fabricating a microelectronic package having polymer ESD protection | United States of America | Expired | 1999-10-19 | 1997-09-25 | 5970321 | 08936829 |
| Apparatus for forming electrical connections between a semiconductor die and a semiconductor package | United States of America | Expired | 1998-08-11 | 1996-02-29 | 5793104 | 08608679 |
| Method for forming electrical connections between a semiconductor die and a semiconductor package | United States of America | Expired | 1999-06-08 | 1997-08-01 | 5911112 | 08904530 |
| Integrated circuit comprising solder bumps | United States of America | Expired | 1998-07-28 | 1997-08-29 | 5786073 | 08922141 |
| Use of plasma activated NF3 to clean solder bumps on a device | United States of America | Expired | 1998-07-07 | 1996-12-23 | 5776551 | 08771955 |
| Corrosion sensitivity structures for vias and contact holes in integrated circuits | United States of America | Granted | 2001-08-21 | 1999-12-15 | 6278129 | 09464225 |
| Corrosion sensitivity structures for vias and contact holes in integrated circuits | United States of America | Granted | 2000-08-15 | 1998-03-19 | 6103615 | 09045062 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Intelligent Software on Automated Test Equipment (ATE) | America | Lapsed | 2009-07-21 | 2007-12-27 | 7565592 | 11964920 |
|---|-----------------------------|-----------|------------|------------|----------|----------|
| Failure Analysis and Testing of Semi-Conductor Devices Using | United States of | | | | | |
| Reduce or Eliminate IMC Cracking in Post Wire Bonded Dies During Cu/Low-K BEOL Processing | United States of America | Granted | 2013-10-08 | 2005-11-18 | 8552560 | 11283219 |
| Alternate Pad Structures/Passivation Integration Schemes to | | | | | | |
| During Cu/Low-K BEOL Processing | America | Abandoned | | 2013-10-03 | | 14045081 |
| Alternate Pad Structures/Passivation Integration Schemes to Reduce or Eliminate IMC Cracking in Post Wire Bonded Dies | United States of | | | | | |
| Circuit Package | America | Granted | 2012-10-16 | 2011-10-04 | 8288269 | 13252632 |
| Methods for Avoiding Parasitic Capacitance in an Integrated | United States of | | | | | |
| Package | America | Granted | 2011-11-01 | 2006-03-22 | 8049340 | 11277188 |
| Device For Avoiding Parasitic Capacitance in an Integrated Circuit | United States of | | | | | |
| Encapsulation of electronic components | America | Expired | 1997-09-02 | 1995-06-07 | 5663872 | 08484177 |
| | United States of | | | | | |
| Encapsulation of electronic components | America | Expired | 1996-07-16 | 1994-10-28 | 5537342 | 08331251 |
| | United States of | | | | | |
| Encapsulation Of Electronic Components | America | Abandoned | | 1992-05-14 | | 07856905 |
| | United States of | | | | | |
| Socketless/boardless test interposer card | America | Lapsed | 2004-08-03 | 2003-04-30 | 6771085 | 10428200 |
| | United States of | | | | | |
| Socketless/Boardless Test Interposer Card | America | Lapsed | 2010-08-17 | 2005-12-30 | RE41516 | 11324119 |
| | United States of | | | | | |
| Socketless/boardless test interposer card | America | Granted | 2003-07-22 | 2002-11-27 | 6597189 | 10306064 |
| | United States of | | | | | |
| Multiple pin die package | America | Expired | 1998-04-14 | 1995-06-07 | 5739584 | 08485060 |
| | United States of | | | | | |
| Plurality of Pins | America | Expired | 1999-02-16 | 1997-08-21 | 5872026 | 08916025 |
| Process of Fabricating An Integrated Circuit Die Package Having a | United States of | | | | | |
| Barrier metal technology for tungsten plug interconnection | America | Expired | 1997-02-04 | 1995-01-24 | 5600182 | 08378027 |
| | United States of | | | | | |
| interconnection | America | Expired | 1998-10-27 | 1996-09-24 | 5827777 | 08718852 |
| Method of making a barrier metal technology for tungsten plug | United States of | | | | | |
| Powdered Metal Heat Sink With Increased Surface Area | America | Expired | 1999-02-09 | 1997-05-12 | 5869891 | 08854780 |
| | United States of | | | | | |
| increased surface area | America | Expired | 1998-09-29 | 1995-12-27 | 5814536 | 08578966 |
| Method of manufacturing powdered metal heat sinks having | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Semiconductor package with traces routed underneath a die | United States of America | Granted | 2000-10-24 | 1999-10-27 | 6137168 | 09428164 |
|---|-----------------------------|-----------|------------|------------|----------|----------|
| Semiconductor device package including a substrate having bonding fingers within an electrically conductive ring surrounding a die area and a combined power and ground plane to stabilize signal path impedances | United States of America | Granted | 2000-05-16 | 1998-01-13 | 6064113 | 09006356 |
| Article Comprising Oxide-Bondable Solder | United States of America | Granted | 2001-10-23 | 1999-12-17 | 6306516 | 09466449 |
| Oxide-Bondable Solder | United States of America | Granted | 2001-11-20 | 2000-08-18 | 6319617 | 09642216 |
| Semiconductor Device Package With Base Features to Reduce Leakage | United States of America | Granted | 2009-06-02 | 2007-04-19 | 7541669 | 11788346 |
| Semiconductor Device Package With Reduced Leakage | United States of America | Granted | 2007-05-29 | 2004-12-18 | 7224047 | 11015534 |
| Chip-over-chip integrated circuit package | United States of America | Granted | 2003-05-06 | 2001-11-05 | 6558978 | 09993466 |
| Vertically integrated flip chip semiconductor package | United States of America | Granted | 2002-04-09 | 2000-01-21 | 6369448 | 09489302 |
| Multi-level redistribution layer traces for reducing current crowding in flipchip solder bumps | United States of America | Granted | 2004-11-16 | 2002-12-20 | 6818996 | 10327333 |
| Multi-Level Redistribution Layer Traces for Reducing Current Crowding in FlipChip Solder Bumps | United States of America | Abandoned | | 2004-08-18 | | 10921497 |
| Bond Pad For A Flip Chip Package, And Method Of Forming The Same | United States of America | Granted | 2001-02-13 | 2000-02-15 | 6187658 | 09503814 |
| Bond Pad For A Flip Chip Package, And Method Of Forming The Same | United States of America | Granted | 2000-07-11 | 1998-09-28 | 6087732 | 09162247 |
| Integrated Circuit With Substantially Perpendicular Wire Bonds | United States of America | Granted | 2008-12-16 | 2006-07-27 | 7465655 | 11494221 |
| Integrated Circuit With Substantially Perpendicular Wire Bonds | United States of America | Granted | 2006-09-19 | 2004-08-26 | 7109589 | 10926631 |
| Electrical Devices Having Adjustable Electrical Characteristics | United States of America | Granted | 2008-11-25 | 2003-12-24 | 7456716 | 10746824 |
| Electrical Devices Having Adjustable Capacitance | United States of America | Granted | 2011-06-14 | 2008-10-17 | 7960812 | 12253403 |
| Failure analysis and testing of semi-conductor devices using intelligent software on automated test equipment (ATE) | United States of America | Granted | 2007-04-10 | 2005-01-04 | 7203877 | 11028695 |
| Failure analysis and testing of semi-conductor devices using intelligent software on automated test equipment (ATE) | United States of America | Granted | 2008-09-30 | 2007-02-01 | 7430700 | 11670031 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Support for semiconductor bond wires | United States of | Grant od | 2001_11_06 | 1005-07-10 | 6213510 | 08/1/878 |
|--|------------------|-----------|------------|------------|----------|----------|
| Substrate Processing System | America | Abandoned | | 2002-12-18 | | 10322974 |
| | United States of | | | | | |
| Substrate processing system | America | Granted | 2003-02-11 | 2001-03-09 | 6518193 | 09802424 |
| | United States of | | | | | |
| semiconductor die | America | Granted | 2008-07-29 | 2005-10-27 | 7405476 | 11260334 |
| Asymmetric alignment of substrate interconnect to | United States of | | | | | |
| Semiconductor Die | America | Granted | 2011-04-05 | 2008-06-13 | 7919354 | 12139185 |
| Asymmetric Alignment of Substrate Interconnect to | United States of | | | | | |
| heat spreading standoff support members | America | Expired | 1999-12-28 | 1997-07-24 | 6008991 | 08903241 |
| Electronic system including packaged integrated circuits with | United States of | | | | | |
| Support member for mounting a microelectronic circuit package | America | Expired | 1999-07-13 | 1996-05-07 | 5923538 | 08646037 |
| | United States of | | | | | |
| Method For Mounting A Microelectronic Circuit Package | America | Expired | 1999-04-27 | 1996-09-12 | 5896651 | 08713174 |
| | United States of | | | | | |
| On A Surface | America | Expired | 1999-04-27 | 1996-09-19 | 5898575 | 08710573 |
| Support Assembly For Mounting An Integrated Circuit Package | United States of | | | | | |
| Location And Standoff Pins For Chip On Tape | America | Expired | 1995-04-25 | 1993-12-20 | 5410451 | 08170102 |
| | United States of | | | | | |
| Location And Standoff Pins For Chip On Tape | America | Abandoned | | 1995-04-24 | | 08427306 |
| | United States of | | | | | |
| Microelectronic Circuit Structure | America | Abandoned | | 1996-05-07 | | 08646014 |
| | United States of | | | | | |
| Leaded Package Including Integral Support Member With Spacer | America | Expired | 1997-10-07 | 1994-10-17 | 5673479 | 08323817 |
| Method For Mounting A Microelectronic Circuit Peripherally- | United States of | | | | | |
| Heat Spreading Stand-Off Support Members | America | Abandoned | | 1995-04-24 | | 08427674 |
| Electronic System Including Packaged Integrated Circuits With | United States of | | | | | |
| mechanism to allow removal of a threaded heat sink therefrom | America | Expired | 1998-08-04 | 1996-09-30 | 5789813 | 08724076 |
| Ball grid array package with inexpensive threaded secure locking | United States of | | | | | |
| Therefrom | America | Expired | 1999-03-23 | 1997-07-28 | 5885848 | 08901489 |
| Locking Mechanism To Allow Removal Of A Threaded Heat Sink | United States of | | | | | |
| Ball Grid Array Package With Inexpensive Threaded Secure | | | | | | |
| Semiconductor Package With Traces Routed Underneath A Die | America | Abandoned | | 2000-07-17 | | 09618143 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Ball Bump Array Semiconductor Packages | United States of America | Abandoned | | 1992-09-01 | | 07938690 |
|---|-----------------------------|-----------|------------|------------|----------|----------|
| Partitions Cost Factor For Non-Square Shaped Partitions | America | Abandoned | | 1993-02-10 | | 08015947 |
| Semiconductor Packaging Technique Yielding Increased Inner Lead Count For A Given Die-Receiving Area | America | Abandoned | | 1994-07-01 | | 08270123 |
| Multi-chip semiconductor arrangements using flip chip dies | United States of America | Expired | 1995-03-21 | 1992-11-12 | 5399898 | 07975185 |
| Overmolded Semiconductor Package | United States of America | Abandoned | | 1996-07-29 | | 08688148 |
| High-density bond pad layout arrangements for semiconductor dies, and connecting to the bond pads | United States of America | Expired | 1997-06-03 | 1995-04-28 | 5635424 | 08430399 |
| Technique of increasing bond pad density on a semiconductor die | United States of America | Expired | 1994-04-05 | 1992-08-25 | 5300815 | 07935449 |
| Package Configuration And Manufacturing Method Enabling The Addition Of Decoupling Capacitors To Standard Package Designs | United States of America | Lapsed | 2009-03-24 | 2005-03-11 | 7508062 | 11078052 |
| Package Configuration And Manufacturing Method Enabling The Addition Of Decoupling Capacitors To Standard Package Designs | United States of America | Lapsed | 2010-11-09 | 2008-07-16 | 7829424 | 12174479 |
| Programmable substrate for array-type packages | United States of America | Granted | 2000-04-25 | 1998-01-13 | 6054767 | 09006584 |
| Method for programming a substrate for array-type packages | United States of America | Granted | 2002-12-10 | 2000-01-04 | 6492253 | 09477306 |
| Chip on tape die reframe process | United States of America | Expired | 2000-03-28 | 1996-04-19 | 6043100 | 08635288 |
| Reframed chip-on-tape die | United States of America | Expired | 1999-11-23 | 1997-08-07 | 5990543 | 08908404 |
| Bonding Pad Design | United States of America | Abandoned | | 2003-10-27 | | 10694486 |
| Method for forming a bonding pad on a substrate | United States of America | Granted | 2004-01-20 | 2001-11-01 | 6678950 | 10007247 |
| Overmolded package body on a substrate | United States of America | Expired | 1999-07-27 | 1997-08-29 | 5927505 | 08920430 |
| Method of improving molding of an overmolded package body on a substrate | United States of America | Expired | 1998-04-28 | 1995-07-24 | 5744084 | 08506164 |
| Support For Semiconductor Bond Wires | United States of America | Abandoned | | 1992-07-15 | | 07914621 |
| litle | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Overmolded semiconductor package | United States of America | Expired | 1996-09-17 | 1995-04-27 | 5557150 | 08429605 |
|---|-----------------------------|-----------|------------|------------|----------|----------|
| Overmolded Semiconductor Package | America | Abandoned | | 1994-10-28 | | 08331263 |
| | United States of | | | | | |
| Overmolded Semiconductor Package | United States of America | Abandoned | | 1992-10-28 | | 07969862 |
| count for a given die-receiving area | America | Expired | 1998-04-28 | 1996-09-26 | 5744858 | 08720219 |
| Semiconductor packaging technique yielding increased inner lead | United States of | | | | | |
| Square Die Shapes | America | Expired | 1995-07-18 | 1993-06-18 | 5434750 | 08079499 |
| Partially-Molded, Pcb Chip Carrier Package For Certain Non- | United States of | | | | | |
| Chip Manufacturing | America | Expired | 1995-05-02 | 1994-02-10 | 5410805 | 08194241 |
| Method And Apparatus For Isolation Of Flux Materials In Flip- | United States of | | | | | |
| The Same | America | Expired | 1998-04-28 | 1900-01-01 | 5744856 | 08476431 |
| Non-Square Die For Integrated Circuit And Systems Containing | United States of | | | | | |
| Mounting And Connecting Non-Square Semiconductor Dies | America | Abandoned | | 1992-12-18 | | 07993188 |
| | United States of | | | | | |
| planar structures | America | Expired | 1998-10-13 | 1995-06-05 | 5821624 | 08470945 |
| Semiconductor device assembly techniques using preformed | United States of | | | | | |
| count per die | America | Expired | 1996-10-15 | 1995-02-10 | 5565385 | 08387154 |
| Semiconductor bond pad structure and increased bond pad | United States of | | | | | |
| Semiconductor bond pads | America | Expired | 1994-02-08 | 1992-11-30 | 5284797 | 07984206 |
| | United States of | | | | | |
| Composite bond pads for semiconductor devices | America | Expired | 1993-09-28 | 1992-09-18 | 5248903 | 07947854 |
| | United States of | | | | | |
| Ball Bump Array Semiconductor Packages | America | Abandoned | | 1995-02-01 | | 08382147 |
| | United States of | | | | | |
| Ball Bump Array Semiconductor Packages | America | Abandoned | | 1992-07-21 | | 07917894 |
| | United States of | | | | | |
| Optically transmissive preformed planar structures | America | Expired | 1998-11-10 | 1996-07-15 | 5834799 | 08679949 |
| | United States of | | | | | |
| Optically Transmissive Preformed Planar Structures | America | Abandoned | | 1993-08-12 | | 08105269 |
| | United States of | | | | | |
| substrate | America | Expired | 1996-04-02 | 1993-08-12 | 5504035 | 08105547 |
| a substrate using a noble metal foil embedded interposer | United States of | | | | | |
| Process for solder ball interconnecting a semiconductor device to | | | | | | |
| Chip Manufacturing | America | Abandoned | | 1989-08-28 | | 07400572 |
| Method And Apparatus For Isolation Of Flux Materials In Flip- | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Solder Bump Structure For Flip Chip Semiconductor Devices And Method Of Manufacturing Therefore | United States of America | Granted | 2013-08-13 | 2011-04-25 | 8507317 | 13093032 |
|---|-----------------------------|-----------|------------|------------|----------|----------|
| Devices and Method Of Manufacture Therefore | America | Abandoned | | 2013-07-02 | | 13934110 |
| Contact Support Pillar Structure for Flip Chip Semiconductor | United States of | | | | | |
| Process for interconnecting conductive substrates using an interposer having conductive plastic filled vias | United States of America | Expired | 1995-11-21 | 1994-06-15 | 5468681 | 08260078 |
| Partially-molded, PCB chip carrier package | America | Expired | 1993-11-16 | 1992-02-07 | 5262927 | 07834182 |
| | United States of | | | | | |
| pads | America | Expired | 1995-04-04 | 1992-12-18 | 5404047 | 07995644 |
| Semiconductor die having a high density array of composite bond | United States of | | | | | |
| chip and a substrate | America | Expired | 1996-02-06 | 1993-08-12 | 5489804 | 08106157 |
| Flexible preformed planar structures for interposing between a | United States of | | | | | |
| manufacturing | America | Expired | 1992-05-05 | 1990-08-30 | 5111279 | 07576182 |
| Apparatus for isolation of flux materials in flip-chip | United States of | | | | | |
| partition cost factor for non-square shaped partitions | America | Expired | 1996-07-02 | 1995-04-03 | 5532934 | 08416457 |
| Floorplanning technique using multi-partitioning based on a | United States of | | | | | |
| Method of laying out bond pads on a semiconductor die | America | Expired | 1995-08-15 | 1994-05-31 | 5441917 | 08251058 |
| | United States of | | | | | |
| count for a given die-receiving area | America | Expired | 1994-07-12 | 1992-08-21 | 5329157 | 07933430 |
| Semiconductor packaging technique yielding increased inner lead | United States of | | | | | |
| packages | America | Expired | 1998-03-24 | 1996-06-14 | 5729894 | 08664146 |
| Method of assembling ball bump grid array semiconductor | United States of | | | | | |
| increasing the ratio of I/O area to active area per die | America | Expired | 1994-08-23 | 1992-11-18 | 5341024 | 07978483 |
| Method of increasing the layout efficiency of dies on a wafer, and | United States of | | | | | |
| increasing the ratio of I/O area to active area per die | America | Expired | 1994-08-23 | 1992-07-17 | 5340772 | 07916328 |
| Method of increasing the layout efficiency of dies on a wafer and | United States of | | | | | |
| die shapes | America | Expired | 1997-01-14 | 1995-05-02 | 5594626 | 08432535 |
| Partially-molded, PCB chip carrier package for certain non-square | United States of | | | | | |
| Preformed planar structures employing embedded conductors | America | Expired | 1994-09-13 | 1993-08-12 | 5347162 | 08105838 |
| | United States of | | | | | |
| assemblies | America | Expired | 1996-10-29 | 1995-04-25 | 5569963 | 08428323 |
| Preformed planar structures for semiconductor device | United States of | | | | | |
| manufacturing | America | Expired | 1992-12-01 | 1991-10-11 | 5168346 | 07775009 |
| Method and apparatus for isolation of flux materials in flip-chip | United States of | | | | | |
| manufacturing | America | Expired | 1994-04-05 | 1992-11-24 | 5299730 | 07981096 |
| Method and apparatus for isolation of flux materials in flip-chip | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Integrated circuit package design with non-orthogonal die cut out | America | Granted | 2004-11-30 | 2002-10-15 | 6825556 | 10271003 |
|---|------------------|-----------|------------|------------|----------|----------|
| | United States of | | | | | |
| Integrated circuit package design | America | Granted | 2008-04-01 | 2004-11-02 | 7352062 | 10979491 |
| | United States of | | | | | |
| Whisker-Free Lead Frames | America | Granted | 2011-09-06 | 2009-07-28 | 8013428 | 12462069 |
| | United States of | | | | | |
| Whisker-Free Lead Frames | America | Abandoned | | 2004-09-28 | | 10951430 |
| | United States of | | | | | |
| Accomodate High Speed Circuitry Ground Isolation | America | Granted | 2012-03-06 | 2009-11-24 | 8129759 | 12625457 |
| Semiconductor Package and Method Using Isolated VSS Plane to | United States of | | | | | |
| Accomodate High Speed Circuitry Ground Isolation | America | Granted | 2010-01-12 | 2006-04-06 | 7646091 | 11399723 |
| Semiconductor Package and Method Using Isolated VSS Plane to | United States of | | | | | |
| Electrostatic Discharge | America | Granted | 2009-03-03 | 2005-12-14 | 7498664 | 11304862 |
| Semiconductor Package Having Increased Resistance to | United States of | | | | | |
| Electrostatic Discharge | America | Granted | 2012-09-04 | 2008-12-17 | 8258016 | 12337519 |
| Semiconductor Package Having Increased Resistance to | United States of | | | | | |
| Method for Heat Dissipation on Semiconductor Device | America | Lapsed | 2014-02-18 | 2013-02-25 | 8653357 | 13775922 |
| | United States of | | | | | |
| Method for Heat Dissipation on Semiconductor Device | America | Granted | 2013-03-26 | 2004-08-31 | 8404960 | 10930590 |
| | United States of | | | | | |
| Solution For Package Cross Talk Minimization | America | Granted | 2012-12-04 | 2009-05-21 | 8324019 | 12469985 |
| | United States of | | | | | |
| Solution For Package Cross Talk Minimization | America | Expired | | 2008-05-23 | | 61055505 |
| | United States of | | | | | |
| Integrated Circuit Package and System Interface | America | Granted | 2009-06-23 | 2008-09-15 | 7550839 | 12283820 |
| | United States of | | | | | |
| Integrated circuit package and system interface | America | Granted | 2008-11-25 | 2006-08-18 | 7456498 | 11506680 |
| | United States of | | | | | |
| Method for probing a semiconductor wafer | America | Granted | 2005-08-09 | 2000-12-06 | 6927079 | 09731596 |
| | United States of | | | | | |
| Probing fixture for semiconductor wafer | America | Granted | 2006-05-30 | 2005-05-18 | 7053639 | 11131885 |
| | United States of | | | | | |
| substrate | America | Expired | 1997-12-23 | 1995-05-03 | 5700715 | 08434276 |
| Process for mounting a semiconductor device to a circuit | United States of | | | | | |
| Generated By Semiconductor Devices | America | Abandoned | | 1994-06-14 | | 08259439 |
| Techniques For Isolating Superconducting Substrates From Heat | United States of | | | | | |
| Method Of Manufacture Therefore | America | Granted | 2011-05-31 | 2006-07-21 | 7952206 | 11459249 |
| Solder Bump Structure For Flip Chip Semiconductor Devices And | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| | | - | | | | | |
|--|-----------------------------|-----------|------------|------------|---|----------|----------|
| I/O and Power ESD Protection Circuits by Enhancing Substrate- Bias In Deep-Submicron CMOS Process | United States of America | Lapsed | 2009-09-01 | 2005-10-25 | | 7582938 | 11258253 |
| Method of balanced coefficient of thermal expansion for flip chip ball grid array | United States of America | Granted | 2004-10-19 | 2003-07-30 | | 6806119 | 10631328 |
| Balanced coefficient of thermal expansion for flip chip ball grid array | United States of America | Granted | 2003-10-28 | 2000-10-06 | | 6639321 | 09680759 |
| Methods And Apparatus For Integrated Circuit Ball Bonding With Substantially Perpendicular Wire Bond Profiles | United States of America | Granted | 2006-07-11 | 2004-02-25 | | 7074705 | 10786182 |
| Methods And Apparatus For Integrated Circuit Ball Bonding With Substantially Perpendicular Wire Bond Profiles | United States of America | Granted | 2011-09-27 | 2006-03-31 | | 8025201 | 11395779 |
| Integrated Circuit Die For Wire Bonding And Flip-Chip Mounting | United States of America | Granted | 2009-06-02 | 2005-06-22 | | 7541674 | 11158435 |
| Integrated Circuit Die For Wire Bonding And Flip-Chip Mounting | United States of America | Granted | 2005-12-06 | 2000-08-15 | | 6972494 | 09639288 |
| Integrated Circuit With Staggered Differential Wire Bond Pairs | United States of America | Granted | 2010-03-09 | 2005-02-25 | | 7675168 | 11065838 |
| Method and Article of Manufacture for Wire Bonding with Staggered Differential Wire Bond Pairs | United States of America | Granted | 2011-12-27 | 2010-01-22 | | 8084857 | 12692209 |
| Multi chip module | United States of America | Lapsed | 2004-01-20 | 2002-10-07 | | 6680532 | 10265751 |
| Multi chip module | United States of America | Granted | 2005-02-22 | 2003-08-11 | | 6858930 | 10638772 |
| Insulated bonding wire for microelectronic packaging | United States of America | Lapsed | 2003-12-30 | 2000-10-12 | | 6670214 | 09687263 |
| Insulated bonding wire tool for microelectronic packaging | United States of America | Lapsed | 2006-01-31 | 2003-08-18 | | 6991147 | 10642706 |
| Routing Under Bond Pad For The Replacement Of An Interconnect Layer | United States of America | Abandoned | | 2012-10-19 | | | 13656092 |
| Routing Under Bond Pad For The Replacement Of An Interconnect Layer | United States of America | Granted | 2012-11-27 | 2006-09-05 | | 8319343 | 11469960 |
| Soldering Method and Related Device for Improved Resistance to Brittle Fracture | United States of America | Abandoned | | 2012-07-18 | | | 13552266 |
| Soldering Method and Related Device for Improved Resistance to Brittle Fracture With An Intermetallic Compound Region Coupling A solder Mass to an NI Layer Which has a low Concentration of P, wherein the amount of P in the underlying NI layer is controlled as a function of the expected volume of the solder mass | United States of America | Granted | 2012-08-14 | 2008-07-10 | | 8242378 | 12160553 |
| Title | Country | Status | GrantDate | FiledDate | 9 | PatentNo | AppNo |

| Integrated Circuit Device Substrates With Selective Epitaxial Growth Thickness Compensation | United States of America | Granted | 2004-04-27 | 2002-03-05 | 6727567 | 10091291 |
|--|-----------------------------|-----------|------------|------------|----------|----------|
| Manufacture Of Dielectrically Isolated Integrated Circuits | United States of America | Granted | 2002-06-25 | 1999-12-15 | 6409829 | 09461609 |
| Method And Apparatus For Assembling Multichip Modules | United States of America | Expired | 1996-10-15 | 1995-06-07 | 5564617 | 08479587 |
| Method and Apparatus for Assembling Multichip Modules | United States of America | Expired | 2000-06-20 | 1992-09-03 | 6077725 | 07940157 |
| Device And Method For Protecting Electronic Component | United States of America | Granted | 2003-04-29 | 2000-05-30 | 6554137 | 09580522 |
| Device And Method For Protecting Electronic Component | United States of America | Granted | 2000-05-30 | 1999-02-05 | 6068130 | 09244857 |
| Heatspreader For A Flip\(miChip Device And Method For Connecting The Heatspreader | United States of America | Granted | 2004-01-27 | 2000-02-02 | 6681482 | 09496989 |
| Heatspreader For A Flip Chip Device, And Method For Connecting The Heatspreader | United States of America | Granted | 2000-09-12 | 1998-11-17 | 6118177 | 09193832 |
| Integrated circuit containing redundant core and peripheral contacts | United States of America | Granted | 2004-03-23 | 2003-06-16 | 6710453 | 10462524 |
| Flip chip testing | United States of America | Granted | 2003-09-09 | 2002-02-01 | 6617181 | 10061518 |
| Plastic Overmolded Packages With Mechanically Decoupled Lid Attach Attachment | United States of America | Granted | 2008-09-09 | 2006-08-16 | 7423341 | 11505152 |
| Plastic Overmolded Packages With Mechanically Decoupled Lid Attach Attachment | United States of America | Granted | 2009-12-15 | 2008-08-15 | 7632717 | 12228720 |
| Bond Pad Design For Integrated Circuits | United States of America | Granted | 2001-03-27 | 1999-05-05 | 6207547 | 09305766 |
| Bond Pad Design For Integrated Circuits | United States of America | Granted | 1999-11-16 | 1998-05-04 | 5986343 | 09072369 |
| Wire Bonding Method For Copper Interconnects In Semiconductor Devices | United States of America | Granted | 2004-09-14 | 1999-12-20 | 6790757 | 09467253 |
| Wire Bonding Method For Copper Interconnects In Semiconductor Devices | United States of America | Abandoned | | 2004-09-10 | | 10939292 |
| Substrate-biased I/O and power ESD protection circuits in deep- submicron twin-well process | United States of America | Granted | 2005-12-27 | 2003-10-01 | 6979869 | 10676602 |
| I/O and Power ESD Protection Circuits by Enhancing Substrate- Bias In Deep-Submicron CMOS Process | United States of America | Granted | 2012-09-18 | 2011-05-18 | 8269280 | 13110581 |
| I/O and Power ESD Protection Circuits by Enhancing Substrate- Bias In Deep-Submicron CMOS Process | United States of America | Granted | 2011-05-24 | 2009-07-21 | 7948036 | 12506746 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 09698175 | 6675450 | 2000-10-30 | 2004-01-13 | Granted | United States of America | Method Of Manufacturing And Mounting Electronic Devices To Limit The Effects Of Parasitics |
|----------|---------|------------|------------|-----------|-----------------------------|---|
| 10742916 | | 2003-12-23 | | Abandoned | United States of America | Method Of Manufacturing And Mounting Electronic Devices To Limit The Effects Of Parasitics |
| 09578082 | 6465884 | 2000-05-24 | 2002-10-15 | Granted | United States of America | Semiconductor Device With Variable Pin Locations |
| 10218783 | 6833286 | 2002-08-14 | 2004-12-21 | Granted | United States of America | Semiconductor Device With Variable Pin Locations |
| 10254473 | 6849936 | 2002-09-25 | 2005-02-01 | Granted | United States of America | System and method for using film deposition techniques to provide an antenna within an integrated circuit package |
| 11012838 | | 2004-12-15 | | Abandoned | United States of America | System and Method For Using Film Deposition Techniques to Provide an Antenna Within an Integrated Circuit Package |
| 10229601 | 6781150 | 2002-08-28 | 2004-08-24 | Granted | United States of America | Test structure for detecting bonding-induced cracks |
| 10856213 | 6998638 | 2004-05-28 | 2006-02-14 | Granted | United States of America | Test structure for detecting bonding-induced cracks |
| 09920144 | | 1900-01-01 | | Abandoned | United States of America | Adhesive Pad Having EMC Shielding Characteristics |
| 09932307 | 6563198 | 2001-08-17 | 2003-05-13 | Granted | United States of America | Adhesive pad having EMC shielding characteristics |
| 08838536 | 6281590 | 1997-04-09 | 2001-08-28 | Expired | United States of America | Circuit And Method For Providing Interconnections Among Individual Integrated Circuit Chips In A Multi-Chip Module |
| 09873551 | 6465336 | 2001-06-04 | 2002-10-15 | Expired | United States of America | Circuit And Method For Providing Interconnections Among Individual Integrated Circuit Chips In A Multi-Chip Module |
| 11868624 | 7429502 | 2007-10-08 | 2008-09-30 | Granted | United States of America | Integrated Circuit Device Incorporating Metallurgical Bond To Enhance Thermal Conduction To A Heat Sink |
| 11235920 | 7327029 | 2005-09-27 | 2008-02-05 | Granted | United States of America | Integrated Circuit Device Incorporating Metallurgical Bond To Enhance Thermal Conduction To A Heat Sink |
| 11448560 | 7301231 | 2006-06-07 | 2007-11-27 | Granted | United States of America | Reinforced Bond Pad For A Semiconductor Device |
| 10955913 | 7115985 | 2004-09-30 | 2006-10-03 | Granted | United States of America | Reinforced Bond Pad For A Semiconductor Device |
| 11379256 | 8601683 | 2006-04-19 | 2013-12-10 | Granted | United States of America | Method for Electrical Interconnection Between Printed Wiring Board Layers Using Through Holes with Solid Core Conductive Material |
| 10755616 | | 2004-01-12 | | Abandoned | United States of America | A Printed Wiring Board Including A Solid Core Conductive Material Located Therein |

| Having A BIST And Bond Pads Incorporated Therein | America | Expired | 2000-10-24 | 1999-04-08 | 6136620 | 09288746 |
|--|------------------|---------|------------|------------|----------|----------|
| A Device And Method Of Manufacture For An Integrated Circuit | United States of | - | | | | |
| Having A BIST Circuit And Bond Pads Incorporated Therein | America | Expired | 1999-10-12 | 1998-02-12 | 5965903 | 09022733 |
| A Device And Method Of Manufacture For An Integrated Circuit | United States of | | | | | |
| Interface Types In A Semiconductor Device | America | Granted | 2010-05-04 | 2007-03-12 | 7709861 | 11684674 |
| Systems And Methods For Supporting a Subset of Multiple | United States of | | | | | |
| Device | America | Granted | 2007-09-18 | 2006-09-11 | 7271485 | 11530550 |
| Systems And Methods For Distributing I\(sIO In A Semiconductor | United States of | | | | | |
| Wire\\miBonding Operation In An Integrated Circuit | America | Granted | 2006-06-06 | 2003-09-29 | 7056819 | 10673703 |
| Methods And Apparatus For Determining Pad Height For A | United States of | | | | | |
| Bonding Operation In An Integrated Circuit | America | Granted | 2010-04-27 | 2006-03-21 | 7705473 | 11385086 |
| Methods And Apparatus For Determining Pad Height For A Wire- | United States of | | | | | |
| Same | America | Expired | 1999-08-17 | 1998-07-31 | 5939641 | 09127707 |
| Stresses In A Molded Package And Power Module Employing The | United States of | | | | | |
| System And Method For Empirically Determining Shrinkage | | | | | | |
| Same | America | Expired | 1999-07-20 | 1997-09-25 | 5925827 | 08938619 |
| Stresses In A Molded Package And Power Module Employing The | United States of | | | | | |
| System And Method For Empirically Determining Shrinkage | | | | | | |
| Flip Chip Semiconductor Device | America | Expired | 2002-08-27 | 2000-06-30 | 6441473 | 09609582 |
| | United States of | | | | | |
| Differential | America | Expired | 2004-12-14 | 2002-06-17 | 6830999 | 10173182 |
| Polymer Layer For Reducing Thermal Expansion Coefficient | United States of | | | | | |
| Method Of Fabricating Flip Chip Semiconductor Device Utilizing | | | | | | |
| Electronic Component Package | America | Granted | 2007-05-29 | 2005-03-15 | 7224076 | 11080859 |
| | United States of | | | | | |
| Electronic Component Package | America | Lapsed | 2005-04-19 | 2002-10-08 | 6881613 | 10266267 |
| | United States of | | | | | |
| Kinetically Controlled Solder Bonding | America | Granted | 2006-03-07 | 2001-10-29 | 7009299 | 10021174 |
| | United States of | | | | | |
| Kinetically Controlled Solder Bonding | America | Granted | 2002-01-29 | 1998-11-20 | 6342442 | 09197074 |
| | United States of | | | | | |
| Adjustment In An Integrated Circuit | America | Granted | 2009-12-29 | 2008-07-11 | 7637414 | 12171903 |
| Methods And Apparatus For Wire Bonding With Wire Length | United States of | | | | | |
| Adjustment In An Integrated Circuit | America | Granted | 2006-08-08 | 2004-02-25 | 7086148 | 10787010 |
| Methods And Apparatus For Wire Bonding With Wire Length | United States of | | | | | |
| Adjustment In An Integrated Circuit | America | Granted | 2008-10-28 | 2006-03-21 | 7443042 | 11385245 |
| Methods And Apparatus For Wire Bonding With Wire Length | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Thermally enhanced tape ball grid array package | America | Granted | 1999-12-14 | 1998-06-15 | 6002169 | | 09097883 |
|--|-------------------|-----------|------------|------------|----------|-----|----------|
| 0 0 | United States of | 170 | 1000 | 1000 | - | | |
| High power dissipating tape ball grid array package | America | Expired | 2000-05-02 | 1997-04-23 | 6057594 | | 08842379 |
| Semiconductor flip chip ball grid array package | America | Granted | 2001-07-24 | 1999-08-16 | 6266249 | | 09375835 |
| G. sees and G. see | United States of | 0.011100 | T000 00 T0 | 10000010 | 1000 | | 001000 |
| integrated circuit package | America | Granted | 2000-05-16 | 1998-06-19 | 6061889 | | 09100665 |
| Device and mother for removing boats provider from an | History States of | Gidillen | CO-00-CO07 | +0-60-T007 | 03/3113 | | 09940033 |
| Integrated circuit having dedicated probe pads for use in testing | United States of | | 7007 06 07 | 2001 | 2,2,2 | | 0004603 |
| Aluminum Bond Pads With Enhanced Wire Bond Stability | America | Granted | 2012-01-24 | 2009-05-26 | 8101871 | | 12471982 |
| | United States of | | | | | | |
| Aluminum Bond Pads With Enhanced Wire Bond Stability | America | Abandoned | | 2012-01-05 | | 7 | 13344207 |
| | United States of | | | | | | |
| Low-Cost 3D Face-to-Face Out Assembly | America | Granted | 2013-08-06 | 2011-08-25 | 8502372 | | 13217857 |
| | United States of | | | | | | |
| Low Cost 3D-Face to Face Fan Out, F2FFO, Assembly | America | Expired | | 2010-08-28 | | | 61377171 |
| | United States of | | | | | | |
| Integrated Circuit Having A Coplanar Solder Ball Contact Array | America | Abandoned | | 1995-12-26 | | 9 | 08578049 |
| | United States of | | | | | | |
| Integrated Circuit Having A Coplanar Solder Ball Contact Array | America | Abandoned | | 1997-09-24 | | | 08936259 |
| | United States of | | | | | | |
| integrated circuit | America | Expired | 1999-11-23 | 1997-08-26 | 5989937 | | 08918451 |
| Method for compensating for bottom warpage of a BGA | United States of | | | | | | |
| Method for planarizing an array of solder balls | America | Expired | 2000-07-18 | 1997-10-30 | 6088914 | | 08960831 |
| | United States of | | | | | | |
| Integrated circuit having a coplanar solder ball contact array | America | Expired | 1995-07-25 | 1994-02-04 | 5435482 | | 08192081 |
| | United States of | | | | | | |
| warpage | America | Expired | 1998-05-05 | 1995-07-24 | 5745986 | | 08506382 |
| on an integrated circuit package to compensate for surface | United States of | | | | | | |
| Method of planarizing an array of plastically deformable contacts | | | | | | | |
| Interposer for semiconductor package assembly | America | Granted | 2003-09-16 | 2001-10-09 | 6618938 | | 09974157 |
| | United States of | | | | | | |
| Interposer for semiconductor package assembly | America | Granted | 2002-01-01 | 2000-02-08 | 6335491 | | 09499801 |
| | United States of | | | | | | |
| Integrated Circuit With Active Devices Under Bond Pads | America | Expired | 1998-05-12 | 1995-10-30 | 5751065 | | 08549990 |
| | United States of | | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | Pat | AppNo |

| Method for making electrical interconnections between layers of an IC package | United States of America | Granted | 1999-11-30 | 1997-11-17 | 5992012 | 08971769 5 |
|--|-----------------------------|---------|------------|------------|----------|--------------|
| electronic packages | America | Expired | 1999-05-25 | 1997-05-29 | 5907189 | 08864994 5 |
| High performance heat spreader for flip chip packages | America | Expired | 1999-06-01 | 1997-06-03 | 5909056 | 08868316 5 |
| | United States of | | | | | |
| Wire Bondable Package Design With Maximum Electrical Performance And Minimum Number Of Layers | Japan | Expired | 2010-07-16 | 1997-05-30 | 4550173 | 1580331997 4 |
| encapsulant injection | | Expired | 2000-07-04 | 1997-08-14 | 6081997 | 08911418 6 |
| System and method for packaging an integrated circuit using | United States of | | | | | |
| Tape ball grid array package with perforated metal stiffener | America | Expired | 1998-11-10 | 1997-09-22 | 5835355 | 08934529 5 |
| | United States of | | | | | |
| Integrated circuit packaging apparatus and method | America | Expired | 2000-10-03 | 1997-08-14 | 6126063 | 08911515 6 |
| | United States of | | | | | |
| package | America | Granted | 2000-09-12 | 1997-11-20 | 6117352 | 08975025 6 |
| permit testing of the integrated circuit and other elements of the | United States of | | | | | |
| Removal of a heat spreader from an integrated circuit package to | | | | | | |
| Removing solder from integrated circuits for failure analysis | America | Granted | 2000-07-04 | 1998-03-31 | 6083848 | 09052884 6 |
| | United States of | | | | | |
| packages | America | Granted | 2001-10-02 | 1998-04-01 | 6297550 | 09053357 6 |
| Bondable anodized aluminum heatspreader for semiconductor | United States of | | | | | |
| Multiple sized die | America | Granted | 2000-03-21 | 1998-01-14 | 6040632 | 09006784 |
| | United States of | | | | | |
| Splitting and assigning power planes | America | Granted | 2002-09-03 | 2001-06-20 | 6445066 | 09885491 6 |
| | United States of | | | | | |
| assembly process | America | Granted | 2000-10-10 | 1998-07-13 | 6130113 | 09114345 6 |
| Enhanced lamination process between heatspreader to pressure sensitive adhesive (PSA) interface as a step in the semiconductor | United States of | | | | | |
| heatspreader | America | Granted | 2000-09-05 | 1998-01-20 | 6114761 | 09009580 6 |
| Thermally-enhanced flip chip IC package with extruded | United States of | | | | | |
| laser marking | America | Granted | 2000-12-05 | 1998-07-24 | 6156676 | 09122335 6 |
| adherence to substrate surface of particles generated during | United States of | | | | | |
| Laser marking of semiconductor wafer substrate while inhibiting | | | | | | |
| Test structure | America | Lapsed | 2005-03-01 | 2002-11-18 | 6861748 | 10298971 6 |
| | United States of | | | | | |
| Electrostatic protected substrate | America | Granted | 2000-11-07 | 1998-06-15 | 6143586 | 09097882 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo PNddA |

| Method of centering a high pressure lid seal | America | Expired | 1997-12-09 | 1995-10-04 | 5695593 | 08538629 |
|---|--------------------|---------|------------|------------|----------|----------|
| | I Inited States of | - | | | | |
| Integrated circuit underfill reservoir | America | Expired | 1998-07-14 | 1996-05-07 | 5780924 | 08644000 |
| | United States of | | | | | |
| Method of packaging integrated circuits | America | Expired | 1998-09-01 | 1996-03-14 | 5801072 | 08615388 |
| | United States of | | | | | |
| Array of solder pads on an integrated circuit | America | Expired | 1998-03-24 | 1996-09-24 | 5731223 | 08719266 |
| | United States of | | | | | |
| stiffener member | America | Expired | 2000-02-01 | 1996-12-12 | 6020221 | 08764039 |
| Process for manufacturing a semiconductor device having a | United States of | | | | | |
| Method of flip chip assembly | America | Expired | 1998-03-03 | 1996-03-14 | 5723369 | 08615865 |
| | United States of | | | | | |
| Semiconductor die having on-die de-coupling capacitance | America | Expired | 1999-09-28 | 1997-03-18 | 5959320 | 08819299 |
| | United States of | | | | | |
| Fluxless solder ball attachment process | America | Expired | 1999-05-04 | 1996-09-20 | 5899737 | 08717601 |
| | United States of | | | | | |
| array packaging of integrated circuits | America | Expired | 1999-10-26 | 1996-12-20 | 5973393 | 08771636 |
| Apparatus and method for stackable molded lead frame ball grid | United States of | | | | | |
| Stiffener with integrated heat sink attachment | America | Expired | 1999-08-17 | 1997-05-02 | 5940271 | 08850076 |
| | United States of | | | | | |
| Stiffener with slots for clip-on heat sink attachment | America | Expired | 1999-11-02 | 1997-04-25 | 5977622 | 08845696 |
| | United States of | | | | | |
| Stacked integrated chip package and method of making same | America | Expired | 1998-09-29 | 1996-12-20 | 5814881 | 08770872 |
| | United States of | | | | | |
| Ball grid array package employing raised metal contact rings | America | Expired | 1998-11-24 | 1997-04-21 | 5841191 | 08837530 |
| | United States of | | | | | |
| PBGA stiffener package | America | Expired | 1999-10-26 | 1997-05-07 | 5972738 | 08852597 |
| | United States of | | | | | |
| Fixture for lid-attachment for encapsulated packages | America | Expired | 2000-05-30 | 1997-05-21 | 6069027 | 08859751 |
| | United States of | | | | | |
| sink or heat spreader/lid | America | Expired | 2000-01-04 | 1997-05-05 | 6011304 | 08850292 |
| Stiffener ring attachment with holes and removable snap-in heat | United States of | | | | | |
| down single-tier package assembly | America | Expired | 1998-11-10 | 1997-05-22 | 5834839 | 08861884 |
| Preserving clearance between encapsulant and PCB for cavity- | United States of | | | | | |
| Molded array integrated circuit package | America | Expired | 2000-09-05 | 1997-09-10 | 6114189 | 08927704 |
| | United States of | | | | | |
| semiconductor package fabrication | America | Expired | 1999-12-07 | 1997-10-27 | 5998242 | 08958776 |
| Vacuum assisted underfill process and apparatus for | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| LOW COSt Ball Glid All ay Package | Allielica | Granted | 87-80-T007 | T0-/0-656T | 9282100 | 09346100 |
|---|--------------------------|-------------|------------|------------|------------|---------------|
| | United States of | | | | | |
| Using Electroplating And Apparatus Made Therefrom | America | Granted | 2007-01-02 | 2004-06-28 | 7157361 | 10878157 |
| Methods For Processing Integrated Circuit Packages Formed | United States of | | | | | |
| Reinforced Bond Pad | United States of America | Granted | 2005-11-01 | 2003-09-30 | 6960836 | 10675260 |
| Flexible Circuit Substrate For Flip-Chip-On-Flex Applications | America | Granted | 2008-07-01 | 2006-02-23 | 7394028 | 11360200 |
| | United States of | | | | | |
| Bond Pad Support Structure For Semiconductor Device | Korea, Republic of (KR) | Lapsed | 2014-02-04 | 2007-10-31 | 10-1360815 | 1020107007877 |
| High Thermal Performance Packaging For Circuit Dies | America | Granted | 2010-08-17 | 2008-07-08 | 7776648 | 12160233 |
| | United States of | | | | | |
| Heat Dissipation In Integrated Circuits | America | Expired | | 2005-09-02 | | 60714214 |
| | United States of | | | | | |
| Integrated Circuit | America | Expired | | 1998-08-05 | | 60095397 |
| An Integrated Circuit Carrier And Method Of Manufacturing And | United States of | | | | | |
| Vacuum-Assisted Integrated Circuit Test Socket | America | Expired | | 1999-08-04 | | 60147106 |
| | United States of | | | | | |
| High speed wafer sort and final test | America | Granted | 2004-08-17 | 2003-03-20 | 6777971 | 10394445 |
| | United States of | | | | | |
| inducing defects after calibration to intrinsic leakage | America | Lapsed | 2008-05-27 | 2005-12-14 | 7379836 | 11300789 |
| Method of using automated test equipment to screen for leakage | United States of | | | | | |
| Wire Bond Integrated Circuit Package For High Speed I/O | European Patent | Application | | 2007-09-27 | | 078524717 |
| Package with Power and Ground Through Silicon Via | Korea, Republic of (KR) | Granted | 2013-11-20 | 2009-01-07 | 10-1333387 | 20117005408 |
| Scaling of functional assignments in packages | America | Granted | 2007-11-20 | 2005-11-18 | 7298036 | 11283340 |
| | United States of | | | | | |
| High Thermal Performance PBGA/FSBGA | European Patent | Application | | 2006-12-21 | | 068480516 |
| Package with Power and Ground Through Silicon Via | Japan | Granted | 2013-08-30 | 2013-02-15 | 5350550 | 2013027597 |
| IMPROVED THERMAL PERFORMANCE | America | Granted | 2009-01-20 | 2007-07-02 | 7479703 | 11772267 |
| INTEGRATED CIRCUIT PACKAGE WITH SPUTTERED HEAT SINK FOR | United States of | | | | | |
| Separate Probe And Bond Regions Of An Integrated Circuit | America | Granted | 2012-02-14 | 2009-04-30 | 8115321 | 12432763 |
| | United States of | | | | | |
| for improved cooling | America | Expired | 1997-04-15 | 1995-09-29 | 5621616 | 08536002 |
| High density CMOS integrated circuit with heat transfer structure | United States of | | | | | |
| tradeoff for latchup behavior | America | Expired | 1998-02-17 | 1995-11-13 | 5719733 | 08556599 |
| ESD protection for deep submicron CMOS devices with minimum | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Hallslator For Necessea Filip-clilp Fackage | 2apan | Gigiifen | 71-00-00-12 | 1999-09-07 | 3803213 | /105071 |
|---|-----------------------------|----------|-------------|------------|-----------|---------------|
| Translator For Recessed Elin-chin Package | | Grantod | 2006-05-12 | 1999-09-07 | 3803213 | 11252017 |
| Flip Chip Assembly of Semiconductor IC Chips | Japan | Granted | 2004-05-14 | 2000-01-20 | 3554695 | 2000012153 |
| Flip Chip Metallization | Japan | Granted | 2004-05-14 | 1999-10-12 | 3554685 | 11289840 |
| Bond Pad Design For Integrated Circuits | Korea, Republic of (KR) | Lapsed | 2002-02-04 | 1999-05-04 | 324832 | 1019990015968 |
| Translator For Recessed Flip-chip Package | Korea, Republic of (KR) | Granted | 2007-08-28 | 1999-09-08 | 754752 | 1019990038064 |
| Brittle Fracture | Taiwan | Granted | 2014-09-11 | 2008-07-21 | 1452657 | 097127688 |
| Individual Integrated Circuit Chips in A Wulti-Chip Module | laiwan | Lapsed | 2001-01-11 | 1998-03-06 | NI-125/82 | 87103290 |
| Circuit And Method For Providing Interconnections Among | | | 2 | | | |
| Chip-On-Chip IC Packages | Taiwan | Lapsed | 2000-12-11 | 1998-09-21 | NI-124614 | 87115697 |
| Flip Chip Assembly of Semiconductor IC Chips | Taiwan | Granted | 2001-08-21 | 2000-04-11 | NI-138749 | 89100891 |
| Testing Integrated Circuits | Taiwan | Granted | 2003-08-01 | 2000-11-01 | NI-182345 | 89122966 |
| die electrical connections | America | Granted | 2007-02-06 | 2004-04-06 | 7173328 | 10819684 |
| Integrated circuit package and method having wire-bonded intra- | United States of | | | | | |
| Electromagnetic interference package protection | United States of America | Granted | 2005-03-15 | 2003-06-10 | 6867480 | 10458130 |
| Dual clock package option | America | Granted | 2004-07-27 | 2003-04-22 | 6768386 | 10420219 |
| | United States of | | | | | |
| Them | America | Expired | 1997-03-04 | 1994-12-20 | 5607882 | 08359973 |
| Multi-Component Electronic Devices and Methods for Making | United States of | | | | | |
| Method for Detecting A Coating Material on A Substrate | America | Expired | 1996-12-10 | 1994-11-29 | 5583285 | 08346454 |
| | United States of | | | | | |
| Solder Bonding Of Dense Arrays Of Microminiature Contact Pads | | Expired | 1999-07-06 | 1995-12-28 | 5918794 | 08581299 |
| | United States of | | | | | |
| Electrostatic discharge protection | America | Granted | 2005-06-28 | 2003-06-06 | 6911736 | 10456281 |
| Interposer For Recessed Flip-Chip Package | | Granted | 2001-01-16 | 1998-09-08 | 6175158 | 09149803 |
| | itates of | | | | | |
| Chip-On-Chip IC Packages | America | Expired | 1999-04-27 | 1997-10-08 | 5898223 | 08946980 |
| | United States of | | | | | |
| Analysis of integrated circuits for high frequency performance | America | Granted | 2006-07-25 | 2003-11-21 | 7082585 | 10718829 |
| | United States of | | | | | |
| Substrate voltage connection | America | Granted | 2004-12-07 | 2003-08-06 | 6828682 | 10635276 |
| | United States of | | | | | |
| Zero capacitance bondpad utilizing active negative capacitance | | Granted | 2006-12-12 | 2003-08-25 | 7148535 | 10647863 |
| | itates of | | | | | 0.000 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Flip chip ball grid array package with laminated substrate | America | Granted | 2000-10-17 | 1999-05-27 | 6133064 | 09322064 |
|---|------------------|---------|------------|------------|-------------------|---------------|
| | United States of | | | | | |
| Substrate position location system | America | Granted | 2002-02-12 | 2000-01-05 | 6347291 | 09478164 |
| | United States of | | | | | |
| underfill layer of an electronic component package | America | Granted | 2001-11-20 | 1999-12-20 | 6320127 | 09465425 |
| Method and structure for reducing the incidence of voiding in an | United States of | | | | | |
| Leadframe Designs For Plastic Overmolded Packages | America | Granted | 2009-07-28 | 2008-03-25 | 7566953 | 12079124 |
| | United States of | | | | | |
| Integrated circuit package via | America | Granted | 2003-04-29 | 2001-10-12 | 6555914 | 09975871 |
| | United States of | | | | | |
| Method for attaching solderballs by selectively oxidizing traces | America | Granted | 2002-08-13 | 2000-06-15 | 6431432 | 09596039 |
| | United States of | | | | | |
| Backside liquid crystal analysis technique for flip-chip packages | America | Granted | 2003-05-06 | 1999-11-16 | 6559670 | 09441543 |
| | United States of | | | | | |
| Flip Chip Bump Bonding | Republic of) | Lapsed | 2011-06-22 | 2000-02-18 | 60046100.9 | 003011756 |
| | Germany (Federal | | | | | |
| Flip Chip Metallization | Republic of) | Granted | 2004-07-14 | 1999-10-05 | 69918631.5 | 993078310 |
| | Germany (Federal | | | | | |
| Manufacture Of Flip-Chip Devices | Republic of) | Lapsed | 2012-02-01 | 1999-02-16 | 69944012.2 | 993011295 |
| microscopy | America (F. 1 | Granted | 2004-05-11 | 2002-11-06 | 6734697 | 10289074 |
| Die location on ungrounded wafer for back-side emission | United States of | | | | | |
| Buffer metal layer | America | Lapsed | 2005-03-01 | 2002-10-09 | 6861343 | 10267410 |
| | United States of | | | | | |
| Attach Attachment | China | Granted | 2011-11-16 | 2007-06-21 | ZL 200710112936.9 | 2007101120369 |
| Plastic Overmolded Packages with Mechanically Decoupled Lid | | | | | | |
| Test fixture for flip chip ball grid array circuits | America | Granted | 2002-08-13 | 2001-05-01 | 6433565 | 09846435 |
| | United States of | | | | | |
| Enhance Thermal Conduction To A Heat Sink | Japan | Lapsed | 2013-04-19 | 2006-09-27 | 5250193 | 2006261623 |
| Integrated Circuit Device Incorporating Metallurgical Bond To | | | | | | |
| Multi chip module assembly | America | Granted | 2006-05-09 | 2002-10-10 | 7041516 | 10268361 |
| | United States of | | | | | |
| Integrated Circuit Packages With Improved EMI Characteristics | Japan | Granted | 2004-08-27 | 2000-09-20 | 3590340 | 2000284630 |
| Top gated heat dissipation | America | Granted | 2003-11-25 | 2002-10-25 | 6654248 | 10280566 |
| | United States of | | | | | |
| Manufacture Of Flip-Chip Devices | Japan | Granted | 2003-12-19 | 1999-03-01 | 3503739 | 11053116 |
| litle | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Integrated circuit package having a stiffener dimensioned to | United States of | 1 | | | | |
|--|--------------------------|---------|------------|------------|----------|------------|
| Apparatus To Decouple Core Circuits Power Supply From Input- Output Circuits Power Supply In A Semiconductor Device Package | Japan | Expired | 2010-08-20 | 1997-05-30 | 4572011 | 1580321997 |
| Integrated heat spreader/stiffener assembly and method of assembly for semiconductor package | United States of America | Expired | 1999-12-14 | 1997-09-22 | 6002171 | 08935834 |
| semiconductor package | America | Expired | 1999-06-01 | 1997-09-23 | 5909057 | 08935424 |
| Integrated heat spreader/stiffener with apertures for | United States of | - | | | | |
| Stiffener ring and heat spreader for use with flip chip packaging assemblies | United States of America | Expired | 1999-09-07 | 1997-09-26 | 5949137 | 08938100 |
| increase integrated circuit I/O pad density | America | Expired | 1999-10-26 | 1997-10-22 | 5973397 | 08955929 |
| Semiconductor device and fabrication method which advantageously combine wire bonding and tab techniques to | United States of | | | | | |
| Semiconductor die metal layout for flip chip packaging | America | Granted | 2000-09-12 | 1997-11-03 | 6118180 | 08963553 |
| | United States of | | | | | |
| Apparatus and method for separating a stiffener member from a flip chip integrated circuit package substrate | America | Granted | 2000-05-30 | 1998-05-13 | 6068727 | 09078093 |
| nigh density signal routing | America | Granted | 70-01-2002 | 7001-06-20 | 6459049 | 09885299 |
| | United States of | • | | | | |
| package adhesive layer | America | Granted | 2000-09-12 | 1998-05-08 | 6117695 | 09075300 |
| Apparatus and method for testing a flip chip integrated circuit | United States of | | | | | |
| method for making the same | America | Granted | 1999-05-11 | 1998-04-30 | 5903050 | 09070671 |
| Semiconductor package having capacitive extension spokes and | United States of | | | | | |
| Use Of Plasma Activated Nf3 To Clean Solder Bumps On A Device | Japan | Granted | 2011-03-25 | 1997-12-24 | 4709336 | 1997355620 |
| Bonding pads over input circuits | America | Granted | 2004-12-07 | 2002-11-04 | 6828643 | 10287668 |
| | United States of | | | | | |
| substrates | America | Granted | 1999-11-09 | 1998-06-25 | 5981311 | 09104838 |
| Process for using a removeable plating bus layer for high density | United States of | | | | | |
| Electroplating fixture for high density substrates | America | Granted | 2000-08-29 | 1998-06-23 | 6110815 | 09103291 |
| | United States of | | | | | |
| substrates | America | Granted | 2002-06-25 | 2001-06-18 | 6411114 | 09884711 |
| Universal test coupon for performing prequalification tests on | United States of | | | | | |
| Overmold integrated circuit package | America | Granted | 2003-02-18 | 2001-08-27 | 6519844 | 09940130 |
| | United States of | | | | | |
| components | America | Granted | 2002-06-04 | 2000-01-28 | 6397944 | 09494070 |
| Heat dissipating apparatus and method for electronic | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | ΑρρΝο |

| System having integrated circuit package with lead frame having internal power and ground busses | United States of America | Expired | 1998-10-06 | 1995-12-29 | 5818102 | 08580800 |
|--|-----------------------------|---------|------------|------------|------------------|---------------|
| Centering lid seal clip apparatus | America | Expired | 1997-02-04 | 1995-10-04 | 5598775 | 08539189 |
| | United States of | | | | | |
| Method of centering a lid seal clip | United States of America | Expired | 1997-05-27 | 1995-10-04 | 5632437 | 08538907 |
| die mounted on a wire bonded die | America | Granted | 2003-02-11 | 2001-03-07 | 6518161 | 09801007 |
| Method for manufacturing a dual chip in package with a flip chip | United States of | | | | | |
| Test Vehicle Data Analysis | China | Lapsed | 2010-04-14 | 2006-03-06 | ZL200610059549.3 | 2006100595493 |
| Test Vehicle Data Analysis | Taiwan | Lapsed | 2013-02-21 | 2006-03-10 | 1386663 | 95108042 |
| integrated circuit | America | Expired | 1995-11-14 | 1994-08-31 | 5465470 | 08299209 |
| Fixture for attaching multiple lids to multi-chip module (MCM) | United States of | | | | | |
| and testing methods | America | Expired | 1998-07-07 | 1996-05-09 | 5777383 | 08647344 |
| Semiconductor chip package with interconnect layers and routing | United States of | | | | | |
| performance and minimum number of layers | America | Expired | 1997-11-25 | 1996-05-31 | 5691568 | 08656033 |
| Wire bondable package design with maxium electrical | United States of | | | | | |
| Configurable ball grid array package | America | Expired | 1998-07-28 | 1995-10-04 | 5786631 | 08539188 |
| | United States of | | | | | |
| High pressure lid seal clip apparatus | America | Expired | 1998-02-10 | 1995-10-04 | 5716493 | 08538630 |
| | United States of | | | | | |
| packages | America | Expired | 1998-06-02 | 1996-04-16 | 5761048 | 08632952 |
| Conductive polymer ball attachment for grid array semiconductor | United States of | | | | | |
| Flip chip package with reduced number of package layers | America | Expired | 1997-11-11 | 1996-03-20 | 5686764 | 08619909 |
| | United States of | | | | | |
| Flip Chip Package With Reduced Number Of Package Layers | Japan | Expired | 2010-09-24 | 1997-03-21 | 4592122 | 09068171 |
| package using solder and film adhesive | Taiwan | Lapsed | 2012-12-11 | 2008-11-10 | 1379364 | 97143311 |
| Process of grounding heat spreader/stiffener to a flip chip | | | | | | |
| Integrated circuit packages with distinctive coloration | America | Expired | 1997-07-01 | 1994-03-01 | 5644102 | 08203919 |
| | United States of | | | | | |
| Semiconductor device package fabrication method and apparatus | America | Expired | 1997-03-11 | 1995-03-27 | 5610442 | 08412087 |
| | United States of | | | | | |
| control | America | Granted | 2003-03-11 | 2001-06-27 | 6531932 | 09894210 |
| Microstrip package having optimized signal line impedance | United States of | | | | | |
| Contact escape pattern | America | Granted | 2002-11-12 | 2001-04-20 | 6479319 | 09839925 |
| | United States of | | | | | |
| Ball grid array package employing solid core solder balls | America | Expired | 1998-11-24 | 1997-04-21 | 5841198 | 08837685 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Process of grounding heat spreader stiffener to a FPBGA using solder and film adhesive | China | Granted | 2012-07-18 | 2008-11-20 | ZL200880127504.2 | 2008801275042 |
|--|------------------|-------------|--------------------|------------|----------------------|---------------|
| POWER CONFIGURATION METHOD FOR STRUCTURED ASICS | America | Granted | 2010-06-15 | 2006-01-19 | 7737564 | 11334870 |
| solder and film adhesive | European Patent | Completed | 2017-01-18 | 2008-11-20 | 2248165 | 088727722 |
| Droops of grounding host spreador stiffsport to a EDBCA using | republic of) | Granten | VT-TO-102 | 7000-11-70 | 201002 | 000/2//22 |
| Process of grounding heat spreader stiffener to a FPBGA using solder and film adhesive | Germany (Federal | Graptod | 2017-01-19 | 2008-11-20 | 77/0165 | 08777777 |
| Package with Power and Ground Through Silicon Via | China | Granted | 2015-04-08 | 2009-01-07 | ZL2009801224755 | 2009801224755 |
| impedance discontinuities in an integrated circuit package design | America | Granted | 2007-02-20 | 2006-03-17 | 7180011 | 11276938 |
| Device for minimizing differential pair length mismatch and | United States of | | | | | |
| Multiple Layers Tape Ball Grid Array Package | Japan | Granted | 2012-08-24 | 2000-08-18 | 5069387 | 2000248741 |
| substrate | America | Granted | 2003-07-01 | 2001-04-26 | 6586825 | 09843443 |
| Dual chip in package with a wire bonded die mounted to a | United States of | | | | | |
| Flexible Circuit Substrate For Flip-Chip-On-Flex Applications | Japan | Granted | 2016-02-12 | 2007-02-23 | 5882390 | 201489934 |
| Flexible Circuit Substrate For Flip-Chip-On-Flex Applications | Republic of) | Granted | 2016-09-21 | 2006-11-03 | 60 2006 050 331.8-08 | 062556691 |
| | Germany (Federal | | | | | |
| Flexible Circuit Substrate For Flip-Chip-On-Flex Applications | European Patent | Completed | 2016-09-21 | 2006-11-03 | 1827067 | 062556691 |
| Incorporating The Same | European Patent | Application | | 2000-10-03 | | 003086758 |
| Multifunction Lead Frame And Integrated Circuit Package | | | | | | |
| Reinforced Bond Pad | Japan | Granted | 2014-06-20 Granted | 2011-09-12 | 5562308 | 2011197816 |
| Mitigation of Whiskers in SN-Films | Japan | Granted | 2016-04-22 | 2008-08-21 | 5922702 | 201495711 |
| Schemes | America | Granted | 2013-01-08 | 2008-05-15 | 8350375 | 12121363 |
| Flipchip Bump Patterns for Efficient I-Mesh Power Distribution | United States of | | | | | |
| Package with Power and Ground Through Via | Taiwan | Granted | 2014-09-21 | 2009-01-21 | 1453875 | 098102349 |
| Power plane for semiconductor device | America | Expired | 1998-11-03 | 1992-01-30 | 5831836 | 07828468 |
| | United States of | | | | | |
| and Flexible Split Locations | America | Granted | 2010-07-06 | 2008-02-21 | 7750460 | 12034745 |
| Ball Grid Array Package Layout Supporting Many Voltage Splits | United States of | | | | | |
| output circuits power supply in a semiconductor device package | America | Expired | 1997-09-30 | 1996-05-30 | 5672911 | 08655599 |
| Apparatus to decouple core circuits power supply from input- | United States of | | | | | |
| Systems having shaped, self-aligning micro-bump structures | America | Expired | 1998-06-16 | 1995-12-18 | 5767580 | 08573892 |
| | United States of | | | | | |
| System having heat dissipating leadframes | America | Expired | 2000-06-20 | 1996-04-01 | 6078502 | 08627411 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Eliminate IMC Cracking in post wirebonded dies: Macro level stress reduction by modifying dielectric/metal film stack in BE layers during Cu/low-k processing | United States of America | Lapsed | 2009-05-12 | 2005-11-30 | 7531442 | 11290087 |
|---|-----------------------------|-------------|------------|------------|----------|-------------|
| Process of grounding heat spreader stiffener to a FPBGA using solder and film adhesive | Japan | Lapsed | 2013-03-22 | 2008-11-20 | 5226087 | 2010548652 |
| Integrated heatspreader for use in wire bonded ball grid array semiconductor packages | United States of America | Granted | 2007-06-26 | 2004-09-10 | 7235889 | 10939082 |
| Post Sn Plate Reflow To Prevent Sn Whisker Formation On Matte Sn\(slNi Plated Cu Lead Frames | United States of America | Expired | | 2004-01-12 | | 60535839 |
| Structure And Method For Fabricating Flip Chip Devices | United States of America | Expired | | 2005-02-24 | | 60655816 |
| Flip Chip Assembly Of Semiconductor IC Chips | European Patent | Abandoned | | 2000-01-13 | | 003002094 |
| Substrate via layout to improve bias humidity testing reliability | United States of America | Granted | 2006-07-25 | 2005-03-07 | 7081672 | 11073802 |
| Integrated Circuit Device Incorporating Metallurgical Bond To Enhance Thermal Conduction To A Heat Sink | Taiwan | Granted | 2011-01-21 | 2006-09-25 | 1336512 | 098108322 |
| Reduce or eliminate IMC cracking in post wire bonded dies by doping Aluminum used in bond pads during Cu/low-k BEOL processing | United States of America | Granted | 2007-04-17 | 2005-11-18 | 7205673 | 11283044 |
| Methods for optimizing package and silicon co-design of integrated circuit | United States of America | Granted | 2006-10-03 | 2004-08-16 | 7117467 | 10918933 |
| Package with Power and Ground Through Silicon Via | European Patent | Application | | 2009-01-07 | | 098133820 |
| Package with Power and Ground Through Silicon Via | Japan | Lapsed | 2014-04-18 | 2009-01-07 | 5525530 | 2011526065 |
| Wire Bond Integrated Circuit Package For High Speed I/O | United States of America | Granted | 2010-09-28 | 2006-12-01 | 7804167 | 11565701 |
| Apparatus suitable for mounting an integrated circuit | United States of America | Granted | 2002-12-17 | 2000-10-24 | 6496374 | 09695540 |
| Process of grounding heat spreader/stiffener to a flip chip package using solder and film adhesive | United States of America | Granted | 2011-06-28 | 2008-02-28 | 7968999 | 12038911 |
| ELECTRONIC COMPONENT CONNECTION SUPPORT STRUCTURES INCLUDING AIR AS A DIELECTRIC | United States of America | Granted | 2009-07-07 | 2006-12-18 | 7557303 | 11641989 |
| Heat sink with chip die EMC ground interconnect | United States of America | Granted | 2002-05-28 | 2001-01-19 | 6396699 | 09766104 |
| Test vehicle data analysis | United States of America | Granted | 2008-05-06 | 2005-04-08 | 7370257 | 11102156 |
| Wire Bond Integrated Circuit Package For High Speed I/O | Taiwan | Granted | 2013-07-21 | 2007-11-21 | 1402958 | 096144051 |
| Process of grounding heat spreader stiffener to a FPBGA using solder and film adhesive | Korea, Republic of (KR) | Granted | 2012-08-20 | 2008-11-20 | 1177039 | 20107018929 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| AppNo | PatentNo | FiledDate | | Status | Country | Title |
|---------------|------------------|------------|------------|---------|---------------------------|--|
| 2010843 | 5731121 | 2010-01-06 | 2015-04-17 | Lapsed | Japan United States of | A Gate Stack Structure For Integrated Circuit Fabrication |
| 11140455 | 7528616 | 2005-05-27 | 2009-05-05 | Lapsed | America | Zero ATE Insertion Force Interposer Daughter Card |
| | | | | | United States of | |
| 60435033 | | 2002-12-20 | | Expired | America | Method Of Bonding TO Copper |
| | | | | | United States of | |
| 11097895 | 7319272 | 2005-04-01 | 2008-01-15 | Granted | America | Ball assignment system |
| | | | | | United States of | Method and apparatus for avoiding dicing chip-outs in integrated |
| 11132751 | 7354790 | 2005-05-18 | 2008-04-08 | Granted | America | circuit die |
| | | | | | | Aluminum Bond Pad And Interconnect Structure For The |
| | | | | | United States of | Replacing An Upper Level Of Copper Interconnect In An |
| 60719234 | | 2005-09-21 | | Expired | America | Integrated Circuit Product |
| | | | | | United States of | Composable System-in-Package Integrated Circuits and Process |
| 11079028 | 7491579 | 2005-03-14 | 2009-02-17 | Lapsed | America | of Composing the Same |
| | | | | | United States of | Construction to improve thermal performance and reduce die |
| 10954940 | 7145232 | 2004-09-30 | 2006-12-05 | Granted | America | backside warpage |
| | | | | | United States of | |
| 10114144 | 6847123 | 2002-04-02 | 2005-01-25 | Granted | America | Vertically staggered bondpad array |
| | | | | | United States of | |
| 10900869 | 7096748 | 2004-07-28 | 2006-08-29 | Granted | America | Embedded strain gauge in printed circuit boards |
| | | | | | United States of | Semiconductor package and process utilizing pre-formed mold |
| 10865179 | 7436060 | 2004-06-09 | 2008-10-14 | Granted | America | cap and heatspreader assembly |
| | | | | | United States of | Structure And Method For Bonding To Copper Interconnect |
| 10741155 | 7328830 | 2003-12-19 | 2008-02-12 | Granted | America | Structures |
| | | | | | United States of | |
| 09631150 | 6369596 | 2000-08-02 | 2002-04-09 | Granted | America | Vacuum-Assisted Integrated Circuit Test Socket |
| | | | | | United States of | Embedded redistribution interposer for footprint compatible chip |
| 10744363 | 7098528 | 2003-12-22 | 2006-08-29 | Granted | America | package conversion |
| | | | | | United States of | Methods And Apparatus To Reduce Growth Formations On |
| 10855148 | 7368326 | 2004-05-27 | 2008-05-06 | Granted | America | Plated Conductive Leads |
| 2006800530073 | ZL200680053007.3 | 2006-12-21 | 2013-07-10 | Granted | China | High Thermal Performance Packaging For Circuit Dies |
| | | | | - | United States of | Integrated Circuit Carrier And Method Of Manufacturing And |
| 09138146 | /02308/ | 17-80-861 | 2006-04-04 | Granted | Allierica | liitegi atea circuit |
| | | | | | United States of | |
| 60014182 | | 2007-12-17 | | Expired | America | Integrated Circuit Package For High\\miSpeed Signals |
| | | | | | United States of | |
| 11468901 | 7633152 | 2006-08-31 | 2009-12-15 | Granted | America | Heat Dissipation In Integrated Circuits |

| Packaging Silicon On Silicon Multichip Modules | United States of America | Expired | 2002-04-09 | 1998-05-19 | 6369444 | 09081448 |
|---|--------------------------------|--------------------|-----------------------|------------|-----------------------|-----------------------------|
| High Thermal Performance Packaging For Circuit Dies | Korea, Republic of (KR) | Granted | 2013-10-24 | 2006-12-21 | 10-1323978 | 20097012892 |
| Soldering Method and Related Device for Improved Resistance to Brittle Fracture | Korea, Republic of (KR) | Granted | 2013-10-02 | 2007-09-21 | 10-1317019 | 20097024392 |
| Dual Damascene Bond Pad Structure For Lowering Stress And Allowing Circuitry Under Pads | United States of America | Granted | 2005-01-04 | 1999-12-16 | 6838769 | 09465089 |
| Structure And Method For Fabricating Flip Chip Devices | United States of America | Granted | 2010-08-17 | 2008-05-30 | 7777333 | 11884328 |
| Method and apparatus for testing of integrated circuit package | United States of America | Granted | 2005-10-11 | 2003-12-04 | 6954082 | 10727474 |
| Integrated Circuit Having Bond Pad With Improved Thermal And Mechanical Properties | United States of America | Lapsed | 2009-03-17 | 2005-12-09 | 7504728 | 11298030 |
| Integrated Circuit Device Having Flexible Leadframe | United States of America | Granted | 2006-04-18 | 2004-04-01 | 7030472 | 10816060 |
| Packaging For Electronic Modules | United States of America | Granted | 2008-10-07 | 2005-02-10 | 7433192 | 11055712 |
| Semiconductor device package substrate probe fixture | United States of America | Granted | 2004-07-06 | 2001-06-19 | 6759860 | 09885687 |
| Enhanced QFN Exposed Pad Geometry To enable PCB Under Package | European Patent | Lapsed | | 2007-02-12 | | 077504819 |
| Structure And Method For Fabricating Flip Chip Devices | China | Lapsed | 2010-03-03 | 2006-02-24 | 200680006014.8 | 2006800060148 |
| Integrated Circuit And A Circuit Board High Thermal Performance Packaging For Circuit Dies | Korea, Republic of (KR) Japan | Granted Granted | 2012-12-10 2012-08-31 | 2006-04-14 | 10-1212473 5073756 | 1020087024806 2009542743 |
| Method And Apparatus For Improving Thermal Energy Dissipation In A Direct-Chip-Attach Coupling Configuration Of An | | | | | | |
| Structure And Method For Fabricating Flip Chip Devices | Korea, Republic of (KR) | Granted | 2013-05-15 | 2006-02-24 | 10-1266335 | 1020077019305 |
| Enhanced QFN Exposed Pad Geometry To enable PCB Under Package | Korea, Republic of (KR) | Lapsed | 2014-01-22 | 2007-02-12 | 10-1356591 | 1020097018981 |
| Bond Pad Support Structure For Semiconductor Device | United States of America | Granted | 2012-05-22 | 2010-03-16 | 8183698 | 12678405 |
| A Quad Flat No Lead (QFN) Integrated Circuit (IC) Package Having a Modified Paddle and Method for Designing the Package | United States of America | Granted | 2012-07-17 | 2009-08-07 | 8222719 | 12526334 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Packaged Integrated Circuit Providing Trace Access To High- Speed Leads | United States of America | Granted | 2006-03-07 | 2003-09-26 | 7009282 | 10672495 |
|--|-----------------------------|-------------|------------|------------|----------|---------------|
| Methods Of Packaging Polarization Maintaining Fibers | America | Granted | 2002-11-12 | 2000-05-30 | 6480657 | 09583126 |
| Method For Testing Integrated Circuits | America Crates of | Granted | 2000-03-28 | 1997-12-16 | 6043670 | 08991867 |
| Air Isolated Crossovers | America | Expired | 2004-01-27 | 1997-10-08 | 6683384 | 08946693 |
| | United States of | | | | | |
| Interconnection | America | Expired | 1997-03-04 | 1995-02-24 | 5608262 | 08393628 |
| Packaging Multi-Chip Modules Without Wire-Bond | United States of | | | | | |
| Layer | America | Granted | 2002-10-15 | 2000-07-21 | 6465882 | 09620939 |
| Integrated Circuit Package Having Partially Exposed Conductive | United States of | | | | | |
| Microelectronic Package With Device Cooling | America | Expired | 1997-12-09 | 1995-10-13 | 5696405 | 08542995 |
| | United States of | | | | | |
| To Performing A Flip Chip Bumping Process | America | Granted | 2007-05-22 | 2004-09-29 | 7221173 | 10953291 |
| Method And Structures For Testing A Semiconductor Wafer Prior | United States of | | | | | |
| Manufacture Of Flip-Chip Devices | America | Granted | 2000-01-18 | 1998-02-27 | 6015652 | 09032338 |
| | United States of | | | | | |
| Flip Chip Metallization | America | Granted | 2000-10-10 | 1998-10-14 | 6130141 | 09172467 |
| | United States of | | | | | |
| Electronic Apparatus | America | Granted | 2001-01-23 | 1999-01-22 | 6178088 | 09235795 |
| | United States of | | | | | |
| Multi-chip package having a contiguous heat spreader assembly | America | Granted | 2005-11-08 | 2003-06-18 | 6963129 | 10464178 |
| | United States of | | | | | |
| reliability | America | Granted | 2008-03-18 | 2003-10-08 | 7345245 | 10681554 |
| Robust high density substrate design for thermal cycling | United States of | | | | | |
| Plastic Packaged Optoelectronic Device | America | Granted | 2002-04-16 | 1999-06-25 | 6371665 | 09344656 |
| | United States of | | | | | |
| Components Incorporated Into The Package | America | Granted | 2010-09-07 | 2003-11-05 | 7791210 | 10702996 |
| Semiconductor Package Having Discrete Non-Active Electrical | United States of | | | | | |
| connected heatspreader | America | Granted | 2005-08-23 | 2003-07-14 | 6933602 | 10620074 |
| Semiconductor package having a thermally and electrically | United States of | | | | | |
| A Quad Flat No Lead Integrated Circuit Package and Method | China | Application | | 2007-02-07 | | 2015100536899 |
| Package | China | Abandoned | | 2007-02-12 | | 2007800522300 |
| Enhanced QFN Exposed Pad Geometry To enable PCB Under | | | | | | |
| Translator For Recessed Flip-chip Package | America | Granted | 2000-12-12 | 1998-09-08 | 6160715 | 09149804 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Bonding pad for low k dielectric | America | Granted | 2004-09-28 | 2003-06-20 | 6798035 | 10600255 6 |
|--|--------------------------|---------|------------|------------|----------|------------|
| | United States of | | | | | |
| Method For Bumping Silicon Devices | America | Expired | 1996-04-09 | 1994-11-02 | 5505367 | 08333168 |
| | United States of | | | | | |
| Wafer-mounted micro-probing platform | United States of America | Granted | 2006-04-04 | 2003-04-16 | 7023225 | 10417049 7 |
| Fabricating High-Q RF Component | America | Granted | 2001-05-15 | 1999-03-02 | 6232047 | 09261093 6 |
| | United States of | | | | | |
| Recessed Flip-Chip Package | America | Granted | 2000-11-28 | 1998-07-21 | 6154370 | 09120148 6 |
| | United States of | | | | | |
| By The Method | America | Granted | 2001-11-20 | 1999-07-12 | 6319450 | 09351945 6 |
| Vented Mold, Method Of Making The Mold, Method Of Encapsulating A Circuit Using The Mold, And Circuit Encapsulated | United States of | | | | | |
| Method And Apparatus For Cutting A Substrate | America | Granted | 2001-03-13 | 1999-07-12 | 6199464 | 09351546 6 |
| | United States of | | | | | |
| Method For Solder-Bonding Contact Pad Arrays | America | Expired | 1997-09-16 | 1996-04-19 | 5667132 | 08633992 5 |
| | United States of | | | | | |
| Multilayer Structures And Process For Fabricating The Same | United States of America | Expired | 1998-11-17 | 1995-12-26 | 5837380 | 08578816 |
| Incorporating The Same | America | Granted | 2002-02-26 | 1999-10-06 | 6351033 | 09413605 6 |
| Multifunction Lead Frame And Integrated Circuit Package | United States of | | | | | |
| Etch Stops And Alignment Marks For Bonded Wafers | America | Granted | 2002-04-16 | 1999-08-30 | 6372600 | 09385735 6 |
| | United States of | | | | | |
| Bonding pad isolation | America | Granted | 2004-06-01 | 2003-08-29 | 6743979 | 10652453 6 |
| | United States of | | | | | |
| MCM With High Q Overlapping Resonator | America | Granted | 2000-06-13 | 1998-01-23 | 6075427 | 09012304 6 |
| | United States of | | | | | |
| Conductive Adhesive Bonding Means | America | Expired | 1998-04-21 | 1996-04-25 | 5741430 | 08638003 5 |
| | United States of | | | | | |
| Electronic Package With Reduced Bending Stress | America | Expired | 1997-05-06 | 1995-04-28 | 5627407 | 08430664 5 |
| | United States of | | | | | |
| Flip Chip Assembly Of Semiconductor IC Chips | America | Granted | 2001-02-20 | 1999-01-21 | 6190940 | 09235011 6 |
| | United States of | | | | | |
| Slot Of A Die Paddle | America | Granted | 2006-11-07 | 2005-03-07 | 7132735 | 11074358 |
| Integrated Circuit Package With Lead Fingers Extending Into A | United States of | | | | | |
| Flip Chip Bump Bonding | America | Granted | 2001-05-15 | 1999-02-23 | 6232212 | 09256443 6 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo P |

| six-to-one signal/power ratio bump and trace pattern for tilp chip design | Onited States of America | Granted | 2003-07-08 | 2000-12-28 | 6591410 | 09752626 |
|---|--------------------------|---------|------------|------------|-----------|----------|
| Interposer For Recessed Flip-Chip Package | Taiwan | Lapsed | 2001-02-21 | 1999-08-11 | NI-127340 | 88113740 |
| Incorporating The Same | Taiwan | Lapsed | 2002-09-05 | 2000-10-02 | NI-155555 | 89120479 |
| Multifunction Lead Frame And Integrated Circuit Package | | | | | | |
| Allowing Circuitry Under Pads | Taiwan | Lapsed | 2002-02-21 | 2001-01-03 | NI-150760 | 89126837 |
| Semiconductor Devices | Taiwan | Granted | 2002-04-24 | 2000-12-14 | NI-147894 | 89126790 |
| PAD Structure And Method Of Forming Same | Taiwan | Granted | 2002-01-01 | 2000-11-23 | NI-147525 | 89124902 |
| Semiconductor Device Having Self-Aligned Contact And Landing | | | | | | |
| Integrated Circuit Package Having Partially Exposed Conductive Layer | Taiwan | Granted | 2002-12-01 | 2001-07-16 | NI-167645 | 90117328 |
| limited integrated circuits | America | Granted | 2004-12-28 | 2003-07-03 | 6836026 | 10614402 |
| Integrated circuit design for both input output limited and core | United States of | | | | | |
| Integrated Circuit Package | Taiwan | Granted | 2002-08-11 | 2001-07-23 | NI-160876 | 90117908 |
| High Performance Multi-Chip IC Package | Taiwan | Granted | 2003-05-19 | 2001-02-02 | NI-170172 | 90102134 |
| Low Profile Integrated Circuit Packages | Taiwan | Lapsed | 2003-02-21 | 2000-10-19 | NI-172446 | 89121960 |
| Flip Chip Metallization | Taiwan | Granted | 2002-02-01 | 1999-08-17 | NI-142196 | 88114052 |
| Flip Chip Bump Bonding | Taiwan | Granted | 2001-11-14 | 2000-04-08 | NI-137162 | 89103182 |
| Multi-Chip Ball Grid Array IC Packages | America | Granted | 2002-08-20 | 2000-03-20 | 6437990 | 09528882 |
| | United States of | | | | | |
| Testing Integrated Circuits | America | Granted | 2002-01-29 | 1999-11-08 | 6342399 | 09435971 |
| | United States of | | | | | |
| Slotted bonding pad | United States of America | Granted | 2004-11-30 | 2003-10-09 | 6825563 | 10683101 |
| A Method Of Manufacturing An Integrated Circuit Package | America | Granted | 2004-09-14 | 2000-07-21 | 6790760 | 09621110 |
| | United States of | | | | | |
| Integrated Circuit Packages With Improved EMI Characteristics | America | Granted | 2001-10-02 | 1999-09-22 | 6297551 | 09401690 |
| | United States of | | | | | |
| High Performance Multi-Chip IC Package | America | Granted | 2004-01-13 | 2000-02-04 | 6678167 | 09498005 |
| | United States of | | | | | |
| Integrated Circuit Package | America | Granted | 2003-01-21 | 2000-07-28 | 6509642 | 09628067 |
| | United States of | | | | | |
| Low Profile Integrated Circuit Packages | America | Granted | 2001-06-26 | 1999-10-22 | 6251705 | 09425706 |
| | United States of | | | | | |
| Isolated stripline structure | America | Granted | 2004-06-01 | 2003-07-08 | 6744130 | 10615063 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 09735085 6605951 | 10347759 6801437 | 1019990006458 682284 | 10396955 7190082 | 1019990049683 662218 | 20000076794 691051 | 1020010043981 675030 | 1020000046915 390229 | 20000078613 687994 | 1019990038065 637008 | 19990028642 0310572 | 2000008193 712772 | 1020010043826 678878 | 095135361 1310597 | 095142149 1411052 | 94132327 1364082 | 10371386 6891392 | | | 09416069 6245993 | Upply II are it is |
|---|------------------------------|----------------------------------|---|---|---|----------------------------|--|---|---|----------------------------|-------------------------|--|---|---|--|---------------------------------|------------------|---|---|--------------------|
| 2000-12-11 | 2003-01-21 | 1999-02-26 | 2003-03-24 | 1999-11-10 | 2000-12-15 | 2001-07-21 | 2000-08-14 | 2000-12-19 | 1999-09-08 | 1999-07-15 | 2000-02-21 | 2001-07-20 | 2006-09-25 | 2006-11-14 | 2005-09-19 | 2003-02-21 | | 2001-07-16 | 1999-10-12 | |
| 2003-08-12 | 2004-10-05 | 2007-02-07 | 2007-03-13 | 2006-12-21 | 2007-02-27 | 2007-01-22 | 2003-06-24 | 2007-02-21 | 2006-10-16 | 2001-09-18 | 2007-04-23 | 2007-01-30 | 2009-06-01 | 2013-10-01 | 2012-05-11 | 2005-05-10 | | 2003-08-11 | 2001-06-12 | |
| Granted | Lapsed | Lapsed | Granted | Granted | Lapsed | Granted | Granted | Lapsed | Granted | Granted | Lapsed | Granted | Granted | Granted | Granted | Granted | | Granted | Granted | |
| United States of America | United States of America | Korea, Republic of (KR) | United States of America | Korea, Republic of (KR) | Korea, Republic of (KR) | Korea, Republic of (KR) | Korea, Republic of (KR) | Korea, Republic of (KR) | Korea, Republic of (KR) | Korea, Republic of (KR) | Korea, Republic of (KR) | Korea, Republic of (KR) | Taiwan | Taiwan | Taiwan | America | United States of | Taiwan | United States of America | |
| Interconnector and method of connecting probes to a die for functional analysis | Electronic organic substrate | Manufacture Of Flip-Chip Devices | Low stress flip-chip package for low-K silicon technology | Heatspreader For A Flip Chip Device, And Method For Connecting The Heatspreader | Dual Damascene Bond Pad Structure for Lowering Stress and Allowing Circuitry Under Pads | Integrated Circuit Package | Integrated Circuit Die For Wire Bonding And Flip-Chip Mounting | Wire Bonding Method For Copper Interconnects In Semiconductor Devices | Interposer For Recessed Flip-Chip Package | Recessed Flip-Chip Package | Flip Chip Bump Bonding | Integrated Circuit Package Having Partially Exposed Conductive Layer | Integrated Circuit Device Incorporating Metallurgical Bond To Enhance Thermal Conduction To A Heat Sink | Flexible Circuit Substrate For Flip-Chip-On-Flex Applications | Method and Structure for Testing a Semiconductor Wafer Prior to Performing a Flip Chip Bumping Process | Substrate impedance measurement | | A Method Of Manufacturing An Integrated Circuit Package | Electronic Assembly Having Shielding And Strain-Relief Member | |

| Multifunction Lead Frame And Integrated Circuit Package Incorporating The Same | Korea, Republic of (KR) | Granted | 2007-07-18 | 2000-10-06 | 742104 | 1020000058790 |
|---|-------------------------|---------|------------|------------|------------|---------------|
| Substrate impedance measurement | America | Granted | 2004-04-06 | 2002-10-09 | 6717423 | 10267814 |
| | United States of | | | | | |
| Plastic Packaged Optoelectronic Device | Japan | Lapsed | 2006-03-24 | 2000-06-23 | 3785026 | 2000189021 |
| Reinforced Bond Pad | Taiwan | Granted | 2012-05-21 | 2004-09-08 | 1364833 | 93127180 |
| regions with multi-layer pad trace conductors | America | Granted | 2004-09-28 | 2003-03-28 | 6798069 | 10402054 |
| Integrated circuit having adaptable core and input/output | United States of | | | | | |
| Recessed Flip-Chip Package | Japan | Granted | 2005-11-18 | 1999-07-19 | 3742252 | 11205181 |
| MCM With High Q Overlapping Resonator | Japan | Granted | 2004-07-23 | 1999-01-20 | 3578931 | 11011396 |
| Integrated Circuit Die For Wire Bonding And Flip-Chip Mounting | Taiwan | Granted | 2002-06-11 | 2000-06-19 | NI-156707 | 089111993 |
| Bond Pad Design For Integrated Circuits | Taiwan | Granted | 2000-10-21 | 1999-03-25 | NI-121715 | 88104689 |
| The Heatspreader | Taiwan | Lapsed | 2001-04-11 | 1999-11-26 | NI-131285 | 88120078 |
| Heatspreader For A Flip Chip Device, And Method For Connecting | | | | | | |
| Bond Pad Design For Integrated Circuits | Japan | Granted | 2006-06-30 | 1999-04-30 | 3821984 | 11123342 |
| Plated Conductive Leads | Korea, Republic of (KR) | Lapsed | 2012-02-17 | 2005-01-11 | 10-1120288 | 20050002443 |
| Methods And Apparatus To Reduce Growth Formations On | | | | | | |
| Methods For Processing Integrated Circuit Packages Formed Using Electroplating And Apparatus Made Therefrom | Korea, Republic of (KR) | Granted | 2014-07-15 | 2005-06-27 | 10-1421714 | 20050055694 |
| Flexible Circuit Substrate For Flip-Chip-On-Flex Applications | Korea, Republic of (KR) | Granted | 2013-08-12 | 2007-02-23 | 10-1297915 | 20070018179 |
| Multi-Chip Ball Grid Array IC Packages | Taiwan | Granted | 2004-10-11 | 2001-03-20 | 1222205 | 90106482 |
| Incorporating The Same | Japan | Granted | 2007-09-07 | 2000-10-06 | 4008195 | 2000306945 |
| Multifunction Lead Frame And Integrated Circuit Package | | | | | | |
| Wire Bonding Method For Copper Interconnects In Semiconductor Devices | Japan | Lapsed | 2006-04-21 | 2000-12-20 | 3796116 | 2000386402 |
| Interleaved termination ring | America | Granted | 2004-06-01 | 2002-10-30 | 6744081 | 10283965 |
| | United States of | | | | | |
| Integrated Circuit Device Incorporating Metallurgical Bond To Enhance Thermal Conduction To A Heat Sink | Korea, Republic of (KR) | Lapsed | 2013-03-13 | 2006-09-27 | 10-1245114 | 1020060094257 |
| Via construction for structural support | America | Granted | 2005-09-13 | 2002-11-08 | 6943446 | 10290953 |
| | United States of | | | | | |
| Reinforced Bond Pad | Korea, Republic of (KR) | Granted | 2012-05-21 | 2004-09-30 | 1150312 | 1020040078075 |
| Donut power mesh scheme for flip chip package | America | Granted | 2004-08-24 | 2003-01-10 | 6781228 | 10339844 |
| | United States of | | | | | |
| litle | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method of rapid wafer bumping | United States of America | Granted | 2002-06-11 | 2000-08-11 | 6403399 | 09636498 |
|--|-----------------------------|---------|------------|--------------------|------------|---------------|
| Circuit And Method For Providing Interconnections Among Individual Integrated Circuit Chips In A Multi-Chip Module | China | Granted | 2004-01-07 | 1998-04-08 | 98106356.X | 98106356X |
| Integrated Circuit Die For Wire Bonding And Flip-Chip Mounting | Japan | Granted | 2008-05-30 | 2000-08-10 | 4130295 | 2000242828 |
| Micromagnetic Components | Japan | Lapsed | 2008-10-03 | 2001-04-19 | 4193019 | 2001120442 |
| Electronic substrate | America | Granted | 2003-08-05 | 2002-10-23 | 6603201 | 10278373 |
| | United States of | Claired | 2014-00-00 | 2000-03-07 | 330204 | 20000001 |
| Integrated Circuit Package With Lead Fingers Extending Into A Slot Of A Die Paddle | lapan | Granted | 2014-05-30 | 5550204 2006-03-07 | 5550204 | 2006060406 |
| Flexible Circuit Substrate For Flip-Chip-On-Flex Applications | Japan | Granted | 2016-03-25 | 2007-02-23 | 5905181 | 2007043174 |
| Method For Solder-Bonding Contact Pad Arrays | Japan | Expired | 2001-03-09 | 1997-04-04 | 3168256 | 09086440 |
| Packaging Silicon On Silicon Multichip Modules | Japan | Granted | 2003-09-26 | 1999-05-19 | 3476708 | 11139175 |
| Method For Testing Integrated Circuits | Japan | Lapsed | 2001-12-07 | 1998-12-14 | 3258285 | 10354961 |
| Integrated Circuit Carrier And Method Of Manufacturing And Integrated Circuit | Japan | Lapsed | 2007-03-16 | 1999-08-05 | 3929651 | 11221875 |
| Flip Chip Bump Bonding | Japan | Granted | 2004-08-20 | 2000-02-22 | 3588027 | 2000044330 |
| Active heat sink | America | Granted | 2003-11-18 | 2002-11-14 | 6648064 | 10298338 |
| | United States of | | | | | |
| Using Electroplating And Apparatus Made Therefrom | Japan | Granted | 2015-01-09 | 2005-06-28 | 5676833 | 2005188120 |
| Mothode For Processing Integrated Circuit Dackages Formed | | | | | | |
| Plastic Overmolded Packages with Mechanically Decoupled Lid Attach Attachment | Korea, Republic of (KR) | Granted | 2014-05-16 | 2007-08-07 | 10-1398404 | 1020070079027 |
| Method Of Manufacture Therefore | Korea, Republic of (KR) | Granted | 2013-07-17 | 2006-09-27 | 10-1288790 | 1020060094340 |
| Integrated Circuit Package With Lead Fingers Extending Into A Slot Of A Die Paddle | Korea, Republic of (KR) | Granted | 2012-09-13 | 2006-03-07 | 10-1184201 | 1020060021401 |
| Speed Leads | Korea, Republic of (KR) | Granted | 2011-08-23 | 2004-09-23 | 10-1060430 | 20040076318 |
| Packaged Integrated Circuit Providing Trace Access To High- | | | | | | |
| Dielectric stack | America | Granted | 2005-11-08 | 2003-02-03 | 6963138 | 10357142 |
| | United States of | | | | | |
| Chip-On-Chip IC Packages | Korea, Republic of (KR) | Granted | 2001-09-25 | 1998-10-08 | 0311356 | 9842014 |
| MCM With High Q Overlapping Resonator | Korea, Republic of (KR) | Granted | 2006-08-23 | 1999-01-23 | 617887 | 1019990002078 |
| Integrated Circuit Carrier And Method Of Manufacturing And Integrated Circuit | Korea, Republic of (KR) | Granted | 2006-09-07 | 1999-08-04 | 623895 | 1019990031985 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Wire bond package with core ring formed over I/O cells | America | Lapsed | 2004-01-06 | 2002-02-20 | 6674176 | 10082027 |
|--|--------------------------|-----------|------------|------------|-------------------|---------------|
| O and one of branch of the state of the stat | I Inited States of | מומוונכם | 70 00 002 | 7007 00 00 | 0,0020, | 1021270 |
| Flip-chip ball grid array package for electromigration testing | America | Granted | 2004-03-02 | 2002-08-05 | 6700207 | 10212448 |
| | Inited States of | | | | | |
| Scatter dots | United States of America | Granted | 2005-03-01 | 2002-11-13 | 6861183 | 10293458 |
| Reducing probe card substrate warpage | America | Granted | 2003-08-12 | 2002-01-23 | 6605954 | 10055812 |
| - | United States of | | | | | |
| Integrated Circuit Packages With Improved EMI Characteristics | Republic of) | Granted | 2008-02-13 | 2000-09-11 | 60037990.6 | 003078318 |
| | Germany (Federal | | | | | |
| Air Isolated Crossovers | Republic of) | Granted | 2007-01-24 | 1998-09-29 | 69836944.0 | 983079161 |
| | Germany (Federal | | | | | |
| Chip-On-Chip IC Packages | Republic of) | Abandoned | | 1998-09-29 | | 983079195 |
| | Germany (Federal | | | | | |
| Plastic Packaged Optoelectronic Device | Republic of) | Granted | 2011-07-04 | 2000-06-13 | 600 45 904.7 | 003050135 |
| | Germany (Federal | | | | | |
| Direct alignment of contacts | America | Granted | 2004-11-09 | 2002-05-08 | 6815812 | 10141252 |
| | United States of | | | | | |
| Individual Integrated Circuit Chips In A Multi-Chip Module | Republic of) | Granted | 2008-08-13 | 1998-03-31 | 69839861.0 | 983025164 |
| Circuit And Method For Providing Interconnections Among | Germany (Federal | | | | | |
| Process For Fabricating Article | Republic of) | Granted | 2004-10-06 | 2000-01-19 | 60014461.5 | 003003696 |
| Article Comprising Aligned, Truncated Carbon Nanotubes And | Germany (Federal | | | | | |
| MCM With High Q Overlapping Resonator | Republic of) | Granted | 2009-07-29 | 1999-01-19 | 69941168.8 | 993003284 |
| | Germany (Federal | | | | | |
| Solder mask on bonding ring | America | Granted | 2004-08-17 | 2002-08-28 | 6777803 | 10229659 |
| | United States of | | | | | |
| copper, nickel, and gold | America | Granted | 2004-08-17 | 2002-08-02 | 6777314 | 10211914 |
| Method of forming electrolytic contact pads including layers of | United States of | | | | | |
| Attach Attachment | Japan | Granted | 2012-11-02 | 2007-08-16 | 5121353 | 2007212015 |
| Plastic Overmolded Packages with Mechanically Decoupled Lid | | | | | | |
| Reinforced Bond Pad | Japan | Lapsed | 2012-03-30 | 2004-09-28 | 4959929 | 2004281010 |
| Method Of Manufacture Therefore | China | Granted | 2009-07-22 | 2006-09-13 | ZL 200610151900.1 | 2006101519001 |
| Collaboration Commission And | 5 | 0 | F000 F0 07 | F 7000 | | 10001010101 |
| Flexible Circuit Substrate For Flip-Chip-On-Flex Applications | China | Granted | 2009-10-07 | 2006-11-30 | 71 200610163067.2 | 2006101630672 |
| Integrated Circuit Device Incorporating Metallurgical Bond To Enhance Thermal Conduction To A Heat Sink | China | Granted | 2010-05-12 | 2006-09-25 | 200610139538.6 | 2006101395386 |
| Simulated voltage contrasted image generator and comparator | America | Granted | 2005-09-27 | 2003-01-22 | 6951000 | 10349770 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Articles comprising Doped Semiconductor Material | America | Expired | 1998-11-10 | 1993-08-25 | 5834/92 | 08111765 |
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| | United States of | | | | | |
| Air Isolated Crossovers | Japan | Lapsed | 2011-02-18 | 1998-10-06 | 4685834 | 2007138865 |
| Layer | Japan | Granted | 2012-11-22 | 2008-02-27 | 5135493 | 2008045768 |
| Integrated Circuit Package Having Partially Exposed Conductive | | | | | | |
| The Heatspreader | Japan | Lapsed | | 2004-06-14 | | 2004175054 |
| Heatspreader For A Flip Chip Device, And Method For Connecting | | | | | | |
| Semiconductor Devices | Japan | Granted | 2009-03-19 | 2000-12-20 | 4279835 | 2005367979 |
| Wire Bonding Method For Copper Interconnects In | | | | | | |
| PAD Structure And Method Of Forming Same | Japan | Abandoned | | 2008-11-13 | | 2008290462 |
| Semiconductor Device Having Self-Aligned Contact And Landing | | | | | | |
| Integrated Circuit Device Having Flexible Leadframe | America | Lapsed | 2009-06-02 | 2005-12-14 | 7541220 | 11302690 |
| | United States of | | | | | |
| Integrated Circuit Bonding Method and Apparatus | America | Expired | 2000-06-13 | 1999-01-28 | 6074897 | 09238706 |
| | United States of | | | | | |
| Dispersoid Particles | America | Expired | 1999-10-12 | 1998-11-06 | 5965197 | 09187885 |
| Article Comprising Fine-Grained Solder Compositions With | United States of | | | | | |
| power management | America | Expired | 1997-07-08 | 1996-08-20 | 5646828 | 08697121 |
| Thin Packaging of multi-chip modules with enhanced thermal | United States of | | | | | |
| Systems and methods for package defect detection | America | Granted | 2003-07-08 | 2001-12-13 | 6590409 | 10023311 |
| | United States of | | | | | |
| Bonding pad interface | America | Granted | 2004-03-16 | 2001-09-07 | 6706622 | 09949207 |
| | United States of | | | | | |
| limit of an integrated circuit | America | Granted | 2003-09-23 | 2002-03-08 | 6623992 | 10094549 |
| System and method for determining a subthreshold leakage test | United States of | | | | | |
| Substrate surface scanning | America | Granted | 2003-06-03 | 2001-12-12 | 6573523 | 10021829 |
| | United States of | | | | | |
| Interposer tape for semiconductor package | America | Granted | 2002-08-06 | 2000-01-06 | 6429534 | 09478972 |
| | United States of | | | | | |
| High density input output | America | Lapsed | 2003-12-30 | 2001-11-27 | 6671865 | 09994567 |
| | United States of | | | | | |
| array | America | Granted | 2004-08-03 | 2001-12-17 | 6769923 | 10024054 |
| Fluted signal pin, cap, membrane, and stanchion for a ball grid | United States of | | | | | |
| Method and apparatus for thermal profiling of flip-chip packages | America | Granted | 2005-11-08 | 1999-12-16 | 6962437 | 09465131 |
| | United States of | | | | | |
| Function Uniformity And Method For Making The Same | Republic of) | Lapsed | 2009-11-25 | 2000-06-13 | 60043373.0 | 003050168 |
| Bonded Article Having Improved Crystalline Structure And Work | Germany (Federal | | | | | |
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| Die clip assembly for semiconductor package | United States of America | Expired | 2000-12-26 | 1997-09-23 | 6166434 | 08935583 |
|---|-----------------------------|---------|------------|------------|----------|----------|
| Dual-thickness solder mask in integrated circuit package | America | Granted | 2001-09-25 | 1999-11-18 | 6294840 | 09443036 |
| | United States of | | | | | |
| Integrated circuit package | United States of America | Expired | 2003-08-05 | 1997-09-12 | 6603200 | 08928826 |
| electronic component package | America | Granted | 2002-05-28 | 1999-12-16 | 6395097 | 09465132 |
| Method and apparatus for cleaning and removing flux from an | United States of | | | | | |
| Non-destructive method of detecting die crack problems | America | Granted | 2002-09-10 | 1999-08-09 | 6449748 | 09370856 |
| | United States of | | | | | |
| Misregistration fidutial | America | Expired | 2000-09-12 | 1997-05-08 | 6115910 | 08853154 |
| | United States of | | | | | |
| weight | America | Granted | 2002-10-15 | 2000-07-10 | 6465338 | 09612867 |
| Method of planarizing die solder balls by employing a die's | United States of | | | | | |
| package | America | Granted | 2002-06-18 | 2000-12-30 | 6407462 | 09753000 |
| Irregular grid bond pad layout arrangement for a flip chip | United States of | | | | | |
| Method for assembling tape ball grid arrays | America | Granted | 2002-07-30 | 1999-10-12 | 6425179 | 09417255 |
| | United States of | | | | | |
| packages | America | Granted | 2001-10-23 | 1999-09-27 | 6306751 | 09406308 |
| Apparatus and method for improving ball joints in semiconductor | United States of | | | | | |
| Integrated circuit test vehicle | America | Lapsed | 2003-03-18 | 2001-08-10 | 6534968 | 09928071 |
| | United States of | | | | | |
| Thin form factor flip chip ball grid array | America | Granted | 2002-08-27 | 2000-08-30 | 6441499 | 09651308 |
| | United States of | | | | | |
| a highly filled fillet | America | Granted | 2002-04-16 | 1999-11-15 | 6373142 | 09440492 |
| Method of adding filler into a non-filled underfill system by using | United States of | | | | | |
| Loose die fixture | America | Granted | 2001-08-28 | 2000-01-20 | 6279889 | 09488438 |
| | United States of | | | | | |
| underfill to manufacture a flip-chip | America | Granted | 2002-11-05 | 1999-11-10 | 6475828 | 09437559 |
| Method of using both a non-filled flux underfill and a filled flux | United States of | | | | | |
| Die power distribution system | America | Granted | 2003-12-02 | 2001-10-01 | 6657870 | 09968286 |
| | United States of | | | | | |
| Integrated Circuit And A Circuit Board | America | Granted | 2010-10-19 | 2006-04-13 | 7817434 | 11403492 |
| Dissipation In A Direct-Chip-Attach Coupling Configuration Of An | United States of | | | | | |
| Method And Apparatus For Improving Thermal Energy | | | | | | |
| Wire Bonding To Copper | America | Granted | 2002-10-29 | 2001-05-24 | 6472304 | 09864577 |
| | United States of | | | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Semiconductor device having a carrier and a multilayer metallization | France | Lapsed | 2002-11-27 | 1996-07-24 | 0756325 | 962020897 0 |
|---|----------------------------------|---------|------------|------------|------------|-------------|
| metallization | European Patent | Expired | 2002-11-27 | 1996-07-24 | 0756325 | 962020897 0 |
| Semiconductor device having a carrier and a multilayer metallization | United States of America | Expired | 1998-03-24 | 1996-07-24 | 5731635 | 08692852 5 |
| Semiconductor device having a carrier and a multilayer metallization | Germany (Federal Republic of) | Expired | 2002-11-27 | 1996-07-24 | 59609905.3 | 962020897 5 |
| Package with Power and Ground Through Via | United States of America | Granted | 2013-01-08 | 2008-09-09 | 8350379 | 12206786 8 |
| Method for reliability testing leakage characteristics in an electronic circuit and a testing device for accomplishing the source | United States of America | Granted | 2004-03-02 | 2001-09-20 | 6701270 | 09957410 6 |
| Characteristic impedance equalizer and an integrated circuit package employing the same | United States of America | Granted | 2004-07-06 | 2001-08-17 | 6759921 | 09932716 6 |
| Backside failure analysis capable integrated circuit packaging | United States of America | Granted | 2001-07-17 | 1998-08-28 | 6261870 | 09143083 6 |
| Universal I/O pad structure for in-line or staggered wire bonding or arrayed flip-chip assembly | United States of America | Granted | 2001-06-05 | 1998-07-31 | 6242814 | 09127486 6 |
| Copper contamination control of in-line probe instruments | United States of America | Granted | 2000-11-21 | 1998-12-15 | 6150175 | 09212366 6 |
| Grooved semiconductor die for flip-chip heat sink attachment | United States of America | Expired | 2001-05-01 | 1997-06-05 | 6225695 | 08869796 6 |
| Cavity down plastic ball grid array multi-chip module | United States of America | Granted | 2000-10-03 | 1999-05-27 | 6127726 | 09321298 6 |
| Routing density enhancement for semiconductor BGA packages and printed wiring boards | United States of America | Granted | 2000-11-21 | 1999-07-01 | 6150729 | 09345432 6 |
| Uniform axial loading ground glass joint clamp | United States of America | Granted | 2001-12-11 | 1999-09-22 | 6328347 | 09400767 6 |
| Plastic ball grid array package with strip line configuration | United States of America | Granted | 2001-05-01 | 1999-12-10 | 6225690 | 09467081 6 |
| Transmission equalization system and an integrated circuit package employing the same | United States of America | Granted | 2002-12-17 | 2001-09-28 | 6496081 | 09967195 6 |
| Multiple layer tape ball grid array package | United States of America | Granted | 2001-09-04 | 1999-08-19 | 6285077 | 09377887 6 |
| Apparatus and method of protecting a probe card during a sort sequence | United States of America | Granted | 2003-09-09 | 2001-08-02 | 6617866 | 09921028 6 |
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| Test Fixture Retainer For An Integrated Circuit Package | United States of America | Granted | 1999-08-10 | 1998-07-27 | 5936849 | 09123370 |
|---|--------------------------|-------------|------------|------------|-----------------|---------------|
| Failure | America | Granted | 2000-11-28 | 1999-03-08 | 6153506 | 09263075 |
| Device And Method Of Controlling The Bowing Of A Soldered Or Adhesively Bonded Assembly | America | Granted | 2001-05-29 | 1999-09-01 | 6239382 | 09388242 |
| Self-Alignment Device For Ball Grid Array Devices | America | Granted | 2001-11-06 | 1999-06-10 | 6313999 | 09329420 |
| Cisconnino con Louis Estate | United States of | Glailfed | 27-00-4002 | 70-00-07 | 0/40222 | 03870322 |
| Method Of Manufacturing A Printed Wiring Board Having A Discontinuous Plating Layer | United States of America | Granted | 2004-05-25 | 2001-06-07 | 6740222 | 09876577 |
| Semiconductor Device | America | Granted | 2006-01-17 | 2003-10-30 | 6987052 | 10697757 |
| Method For Making Enhanced Substrate Contact For A | United States of | | | | | |
| Packages | America | Granted | 2006-07-11 | 2004-02-26 | 7075174 | 10788162 |
| Semiconductor Packaging Techniques For Use With Non-Ceramic | United States of | | | | | |
| Enhanced Substrate Contact For A Semiconductor Device | America | Granted | 2006-05-09 | 2004-03-31 | 7041561 | 10814062 |
| | United States of | | | | | |
| Integrated Circuit Die | America | Granted | 2010-06-29 | 2004-06-29 | 7745927 | 10879909 |
| Heat Sink Formed Of Multiple Metal Layers On Backside Of | United States of | | | | | |
| Robust Electronic Device Packages | America | Granted | 2005-05-17 | 2004-05-25 | 6894400 | 10853395 |
| | United States of | | | | | |
| Applications | America | Granted | 2010-02-23 | 2007-03-12 | 7667321 | 11717227 |
| Wire Bonding Method And Related Device For High-Frequency | United States of | | | | | |
| An Electronic Device Package and Method of Manufacture | America | Lapsed | 2013-02-26 | 2011-07-01 | 8384205 | 13174970 |
| | United States of | | | | | |
| An Electronic Device Package And Method Of Manufacture | Singapore | Lapsed | 2013-07-31 | 2010-06-10 | 167757 | 2010040590 |
| Electronic Device Package And Method Of Manufacture | Korea, Republic of (KR) | Abandoned | | 2010-06-10 | | 1020100054807 |
| Electronic Device Package And Method Of Manufacture | Japan | Lapsed | 2015-07-31 | 2010-06-10 | 5784280 | 2010132552 |
| Electronic Device Package And Method Of Manufacture | China | Lapsed | 2016-01-06 | 2010-06-10 | ZL2010102027867 | 2010102027867 |
| Electronic Device Package And Method Of Manufacture | America | Lapsed | 2011-08-09 | 2009-06-11 | 7993981 | 12483139 |
| | United States of | | | | | |
| Electronic Device Package And Method Of Manufacture | Taiwan | Lapsed | 2013-10-21 | 2010-06-10 | 1413210 | 099118956 |
| Electronic Device Package And Method Of Manufacture | European Patent | Application | | 2010-06-11 | | 101657385 |
| Semiconductor device having a carrier and a multilayer metallization | Netherlands | Lapsed | 2002-11-27 | 1996-07-24 | 0756325 | 962020897 |
| metallization | United Kingdom | Lapsed | 2002-11-27 | 1996-07-24 | 0756325 | 962020897 |
| Semiconductor device having a carrier and a multilayer | | | 2222000 | | | |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | ΑρρΝο |

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| | | | | | United States of | |
| 09073279 | 6057700 | 1998-05-06 | 2000-05-02 | Granted | America | Pressure Controlled Alignment Fixture |
| | | | | | United States of | |
| 08956527 | 5975408 | 1997-10-23 | 1999-11-02 | Granted | America | Solder Bonding Of Electrical Components |
| 08824574 | 5975836 | 1997-03-26 | 1999-11-02 | Expired | United States of America | Apparatus For Visually Reading Semiconductor Wafer Identification Indicia |
| 08724129 | 5719449 | 1996-09-30 | 1998-02-17 | Expired | United States of America | Flip-Chip Integrated Circuit With Improved Testability |
| 08663336 | 5672913 | 1996-06-13 | 1997-09-30 | Expired | United States of America | Semiconductor Device Having A Layer Of Gallium Amalgam On Bump Leads |
| 08366539 | 5501777 | 1994-12-30 | 1996-03-26 | Expired | United States of America | Method For Testing Solder Mask Material |
| 00000000 | | 1777 117 | 10000 | 7 | United States of | 0 00000 |
| 12119575 | 7554133 | 2008-05-13 | 2009-06-30 | Granted | America | PAD CURRENT SPLITTING |
| 13032429 | 8547681 | 2011-02-22 | 2013-10-01 | Granted | Onited States of America | Decoupling Capacitor |
| 12061728 | 8134232 | 2008-04-03 | 2012-03-13 | Granted | United States of America | HEAT DISSIPATION FOR INTEGRATED CIRCUIT |
| 098124922 | 1401440 | 2009-07-23 | 2013-07-11 | Granted | Taiwan | Circuit Apparatus Including Removable Bond Pad Extension |
| 12463718 | 7724023 | 2009-05-11 | 2010-05-25 | Granted | United States of America | Circuit Apparatus Including Removable Bond Pad Extension |
| 2009234710 | 5676868 | 2009-10-09 | 2015-01-09 | Granted | Japan | Circuit Apparatus Including Removable Bond Pad Extension |
| 2009056979 | 166712 | 2009-08-26 | 2012-07-13 | Lapsed | Singapore | Circuit Apparatus Including Removable Bond Pad Extension |
| 101564813 | 2251703 | 2010-03-15 | 2012-01-25 | Completed | European Patent | Circuit Apparatus Including Removable Bond Pad Extension |
| 101564813 | 602010000720.0 | 2010-03-15 | 2012-01-25 | Lapsed | Germany (Federal Republic of) | Circuit Apparatus Including Removable Bond Pad Extension |
| 1020090085791 | 10-1420174 | 2009-09-11 | 2014-07-10 | Granted | Korea, Republic of (KR) | Circuit Apparatus Including Removable Bond Pad Extension |
| 101564813 | 2251703 | 2010-03-15 | 2012-01-25 | Lapsed | United Kingdom | Circuit Apparatus Including Removable Bond Pad Extension |
| 12501686 | 8378485 | 2009-07-13 | 2013-02-19 | Granted | United States of America | Improvement Of Solder Interconnect By Addition Of Copper |
| 1020100066127 | 10-1704030 | 2010-07-09 | 2017-02-01 | Granted | Korea, Republic of (KR) | Improvement Of Solder Interconnect By Addition Of Copper |
| 099122029 | 1394632 | 2010-07-05 | 2013-05-01 | Lapsed | Taiwan | Improvement Of Solder Interconnect By Addition Of Copper |
| 101690105 | | 2010-07-09 | | Abandoned | European Patent | Improvement Of Solder Interconnect By Addition Of Copper |
| 2010158372 | 5604665 | 2010-07-13 | 2014-09-05 | Granted | Japan | Improvement Of Solder Interconnect By Addition Of Copper |
| 2010102269692 | ZL201010226969.2 | 2010-07-12 | 2014-09-03 | Granted | China | Improvement Of Solder Interconnect By Addition Of Copper |

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| 13752524 | 8580621 | 2013-01-29 | 2013-11-12 | Granted | America | Solder Interconnect By Addition Of Copper |
| | | | | | United States of | |
| 12327987 | 7787252 | 2008-12-04 | 2010-08-31 | Granted | America | Preferentially Cooled Electronic Device |
| 2010102027994 | 10 1930935 | 2010-06-10 | 2014-07-23 | Granted | China | Lead Frame Design To Improve Reliability |
| 099118954 | 1411082 | 2010-06-10 | 2013-10-01 | Granted | Taiwan | Lead Frame Design To Improve Reliability |
| | | | | | United States of | |
| 12486592 | 8334467 | 2009-06-17 | 2012-12-18 | Granted | America | Lead Frame Design To Improve Reliability |
| 101659696 | | 2010-06-15 | | Application | European Patent | Lead Frame Design To Improve Reliability |
| 1020100055837 | 10-1676038 | 2010-06-14 | 2016-11-08 | Granted | Korea, Republic of (KR) | Lead Frame Design To Improve Reliability |
| | | | | | United States of | |
| 13677547 | 8869389 | 2012-11-15 | 2014-10-28 | Granted | America | Method of Manufacturing an Electronic Device Package |
| | | | | | United States of | A Method Of Generating A Leadframe IC Package Model, A |
| 12485238 | 8370777 | 2009-06-16 | 2013-02-05 | Lapsed | America | Leadframe Modeler And An IC Design System |
| | | | | | United States of | |
| 12331561 | 8125091 | 2008-12-10 | 2012-02-28 | Granted | America | Wire bonding over active circuits |
| 200880130797X | ZL200880130797.X | 2008-08-21 | 2014-01-29 | Lapsed | China | Mitigation of Whiskers in SN-Films |
| 2011523783 | | 2008-08-21 | | Abandoned | Japan | Mitigation of Whiskers in SN-Films |
| 088199641 | | 2008-08-21 | | Abandoned | European Patent | Mitigation of Whiskers in SN-Films |
| | | | | | United States of | |
| 13059502 | 8653375 | 2011-02-17 | 2014-02-18 | Granted | America | Mitigation of Whiskers in SN-Films |
| 098127625 | 1399461 | 2009-08-17 | 2013-06-21 | Granted | Taiwan | Mitigation of Whiskers in SN-Films |
| | | | | | United States of | |
| 12060387 | 7671450 | 2008-04-01 | 2010-03-02 | Granted | America | Integrated Circuit Package For High-Speed Signals |
| | | | | | United States of | |
| 12220182 | 7727781 | 2008-07-22 | 2010-06-01 | Granted | America | Manufacture Of Devices Including Solder Bumps |
| | | | | | United States of | |
| 12154794 | 7724359 | 2008-05-27 | 2010-05-25 | Granted | America | A Method Of Making Electronic Entities |
| | | | | | United States of | Integration of Shallow Trench Isolation and Through-Substrate |
| 12969852 | 8742535 | 2010-12-16 | 2014-06-03 | Granted | America | Vias into Integrated Circuit Designs |
| | | | | | | Integration of Shallow Trench Isolation and Through-Substrate |
| 2011273948 | 5670306 | 2011-12-15 | 2014-12-26 | Granted | Japan | Vias into Integrated Circuit Designs |
| | | | | | | Integration of Shallow Trench Isolation and Through-Substrate |
| 2011104217470 | ZL2011104217470 | 2011-12-16 | 2015-01-21 | Granted | China | Vias into Integrated Circuit Designs |
| | | | | | | Integration of Shallow Trench Isolation and Through-Substrate |
| 111930921 | | 2011-12-12 | | Application | European Patent | Vias into Integrated Circuit Designs |

| Method Of Testing Electronic Wafers Having Lead-Free Solder | United States of | | | 7005 07 07 | 7005000 | |
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| Integrated Circuit With Heat Conducting Structures For Localized Thermal Control | United States of America | Granted | 2014-03-04 | 2005-06-22 | 8664759 | 11158370 |
| Low Thermal Resistance Assembly for Flip Chip Applications | United States of America | Lapsed | 2009-01-20 | 2006-03-14 | 7479695 | 11375302 |
| Thermal Monitoring And Management Of Integrated Circuits | America | Granted | 2011-07-05 | 2008-08-20 | 7973544 | 12194706 |
| | United States of | | | | | |
| On-Chip Sensor Array For Temperature Management In Integrated Circuits | United States of America | Granted | 2010-09-21 | 2006-07-27 | 7800879 | 11460459 |
| Conductive Features Arranged In Aperture Of Circuit Substrate | America | Granted | 2011-07-19 | 2006-11-22 | 7982307 | 11562537 |
| Integrated Circuit Chip Assembly Having Array Of Thermally | United States of | | | | | |
| Stacked Interconnect Heat Sink | China | Abandoned | | 2011-07-18 | | 2011101997470 |
| (R) Stacked Interconnect Heat Sink | Korea, Republic of (KR) | Application | | 2011-07-19 | | 1020110071262 |
| Stacked Interconnect Heat Sink | America | Granted | 2013-07-23 | 2010-07-20 | 8492911 | 12840016 |
| | United States of | | | | | |
| Stacked Interconnect Heat Sink | United States of America | Abandoned | | 2015-04-03 | | 14678223 |
| Stacked Interconnect Heat Sink | Taiwan | Granted | 2013-10-21 | 2011-06-21 | 1413222 | 100121685 |
| Stacked Interconnect Heat Sink | Japan | Granted | 2016-02-19 | 2011-07-20 | 5885952 | 2011158573 |
| Stacked Interconnect Heat Sink | European Patent | Application | | 2011-07-20 | | 111747341 |
| Stacked Interconnect Heat Sink | America | Granted | 2015-06-09 | 2013-06-19 | 9054064 | 13921707 |
| | United States of | | | | | |
| Integrated Circuit Package Including Wire Bonds | United States of America | Granted | 2011-02-15 | 2007-10-10 | 7888257 | 11973859 |
| Method of Fabrication of Through-Substrate Vias | America | Granted | 2015-03-24 | 2010-12-16 | 8987137 | 12969836 |
| | United States of | | | | | |
| Electronic Packages | America | Granted | 2010-03-02 | 2008-05-02 | 7671436 | 12151108 |
| | United States of | | | | | |
| Vias into Integrated Circuit Designs | America | Granted | 2017-04-04 | 2014-04-11 | 9613847 | 14251258 |
| Integration of Shallow Trench Isolation and Through-Substrate | United States of | | | | | |
| Integration of Shallow Trench Isolation and Through-Substrate Vias into Integrated Circuit Designs | Taiwan | Granted | 2014-12-01 | 2011-11-23 | 1463584 | 100142971 |
| | Korea, Republic of (KR) | Granted | 2014-12-15 | 2011-12-14 | 10-1475108 | 1020110134104 |
| Integration of Shallow Trench Isolation and Through-Substrate | | | | | | |

| Dual In-Line BGA Ball Mounter | America | Granted | 2002-07-02 | 2000-09-26 | 6412680 | 09669278 |
|---|--------------------------|---------|------------|------------|----------|-----------|
| - Contract of the contract of | United States of | 0.01 | TOOL 00 TO | TO 00 07 | | |
| A Technique For Reducing Dambar Burrs | America | Granted | 2002-03-19 | 2000-07-12 | 6358779 | 09614854 |
| | I nited States of | | | | | |
| Integrated Circuit Package With Improved ESD Protection For No-Connect Pins | United States of America | Granted | 2002-11-05 | 2000-08-18 | 6476472 | 09641899 |
| Region And Method Of Manufacturing Same | America | Granted | 2003-09-30 | 2002-05-17 | 6628001 | 10150790 |
| Integrated Circuit Die Having Alignment Marks In The Bond Pad | United States of | | | | | |
| Stacked Ball Bumps | America | Granted | 2006-03-07 | 2004-06-30 | 7009305 | 10881191 |
| Methods And Apparatus For Integrated Circuit Ball Bonding Using | United States of | | | | | |
| Operation | America | Granted | 2006-10-17 | 2004-10-07 | 7122892 | 10960680 |
| Multi-Chip Integrated Circuit Module For High-Frequency | United States of | | | | | |
| Device Packages Having Stable Wirebonds | America | Granted | 2008-01-01 | 2003-11-05 | 7314781 | 10702875 |
| | United States of | | | | | |
| System And Method For Forming Solder Joints | America | Granted | 2008-05-06 | 2004-09-30 | 7367486 | 10955912 |
| | United States of | | | | | |
| Distribution Via Internal Wire Bonds | America | Granted | 2008-09-30 | 2003-11-26 | 7429703 | 10722652 |
| Methods And Apparatus For Integrated Circuit Device Power | United States of | | | | | |
| Techniques For Reducing Bowing In Power Transistor Devices | America | Granted | 2007-01-16 | 2004-02-27 | 7164200 | 10788678 |
| | United States of | | | | | |
| Device Packages | America | Granted | 2007-06-26 | 2005-02-02 | 7235422 | 11049246 |
| | United States of | | | | | |
| Device Package | America | Granted | 2007-07-10 | 2005-02-02 | 7242090 | 11049407 |
| | United States of | | | | | |
| Controlling Warping In Integrated Circuit Devices | America | Granted | 2011-04-12 | 2009-08-24 | 7923347 | 12546083 |
| | United States of | | | | | |
| Controlling Warping In Integrated Circuit Devices | Japan | Granted | 2014-12-05 | 2006-03-31 | 5657188 | 200696225 |
| Controlling Warping In Integrated Circuit Devices | America | Granted | 2009-10-06 | 2008-06-27 | 7598602 | 12163453 |
| | United States of | | | | | |
| Controlling Warping In Integrated Circuit Devices | America | Granted | 2012-03-13 | 2011-03-07 | 8133799 | 13041674 |
| | United States of | | | | | |
| Controlling Warping In Integrated Circuit Devices | America | Granted | 2008-08-05 | 2005-03-31 | 7408246 | 11095929 |
| | United States of | | | | | |
| Of Making Same | America | Granted | 2011-06-07 | 2004-12-18 | 7956451 | 11015535 |
| Packages For Encapsulated Semiconductor Devices And Method | United States of | | | | | |
| Leadframe Designs For Integrated Circuit Plastic Packages | America | Granted | 2007-05-22 | 2004-11-24 | 7221042 | 10997630 |
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| Method For Forming Integrated Composite Semiconductor | United States of | | | | | |
| Overcast Semiconductor Package | United States of America | Granted | 2000-03-07 | 1997-11-26 | 6034441 | 08979063 6 |
| Flip Chips Metalization | America | Expired | 1999-05-18 | 1997-04-02 | 5904859 | 08825923 5 |
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| Negative CTE Material Disposed Within A Positive CTE Matrix | America | Granted | 2001-12-04 | 1998-05-04 | 6326685 | 09072248 6 |
| Low Thermal Expansion Composite Comprising Bodies Of | United States of | | | | | |
| Array | America | Granted | 1999-09-21 | 1998-10-08 | 5955683 | 09169117 5 |
| Method and Appartus for Detecting a Solder Bridge in a Ball Grid | United States of | | | | | |
| Article Comprising Molded Circuit | America | Granted | 2000-08-29 | 1998-10-16 | 6110576 | 09173502 6 |
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| Electronic Assembly Having Improved Resistance to Delamination | America | Granted | 2000-02-22 | 1998-08-13 | 6028772 | 09133606 |
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| Measurement Of Mechanical Fastener Clamping Force | America | Granted | 2000-11-14 | 1998-12-29 | 6145385 | 09221726 6 |
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| Integrated Circuit Connections With Flip-Chip Bonding | America | Granted | 2000-10-31 | 1999-05-05 | 6140710 | 09305732 6 |
| Power And Ground And Signal Layout For Higher Density | United States of | | | | | |
| A BALL GRID ARRAY | America | Granted | 2000-03-28 | 1998-10-08 | 6043876 | 09168638 |
| METHOD AND APPARATUS FOR DETECTING A SOLDER BRIDGE IN | United States of | | | | | |
| Fixture And A Device Under Test | America | Granted | 2001-06-26 | 2000-01-10 | 6252289 | 09480014 6 |
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| Die Coating Material Stirring Machine | America | Granted | 2001-10-30 | 2000-01-27 | 6309097 | 09492600 6 |
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| Active Circuitry | America | Granted | 2002-07-09 | 1999-12-16 | 6417087 | 09465075 |
| Process For Forming A Dual Damascene Bond Pad Structure Over | United States of | | | | | |
| Lead Structure For Sealing Package | America | Granted | 2003-05-06 | 2001-02-13 | 6559535 | 09781423 6 |
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| 08761047 | 5747982 | 1996-12-05 | 1998-05-05 | Expired | America | Multi-Chip Modules With Isolated Coupling Between Modules |
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| 09058505 | 6125042 | 1998-04-10 | 2000-09-26 | Granted | America | Characteristics |
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| 08486844 | 5646451 | 1995-06-07 | 1997-07-08 | Expired | America | Multifunctional Chip Wire Bonds |
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| | | | | | United States of | |
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| Advanced modular cell placement system | United States of America | Expired | 2001-09-18 | 1999-11-22 | 6292929 | 09444975 |
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| Advanced modular cell placement system | United States of America | Expired | 2000-05-23 | 1997-02-11 | 6067409 | 08798598 |
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| Comparing aerial image to SEM of photoresist or substrate pattern for masking process characterization | United States of America | Expired | 2000-06-20 | 1997-05-08 | 6078738 | 08853155 |
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| Separable cells having wiring channels for routing signals between surrounding cells | United States of America | Expired | 1999-05-18 | 1997-06-09 | 5905655 | 08871212 |
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| Elmore model enhancement | United States of America | Granted | 2003-04-01 | 2001-01-26 | 6543038 | 09771272 |
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| Estimation of Clock Buffer Output resistance | United States of America | Expired | | 2000-09-28 | | 60236902 |
| Optimization processing for integrated circuit physical design automation system using parallel moving windows | United States of America | Expired | 1999-02-09 | 1997-12-09 | 5870313 | 08987865 |
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| Performing optical proximity correction with the aid of design rule checkers | United States of America | Expired | 1998-01-06 | 1996-02-27 | 5705301 | 08607398 |
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| Built-In Self Repair Circuitry Utilizing Permanent Record Of Defects | United States of America | Abandoned | | 1999-01-26 | | 09237769 |
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| Density driven layout for RRAM configuration module | United States of America | Granted | 2007-07-17 | 2004-12-08 | 7246337 | 11007039 |
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| Ramptime propagation on designs with cycles | United States of America | Granted | 2007-07-17 | 2004-12-03 | 7246336 | 11004309 |
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| NQL - Netlist Query Language | United States of America | Lapsed | 2009-01-20 | 2007-08-01 | 7480650 | 11832516 |
| Method of fabricating a linearly continuous integrated circuit gate array | United States of America | Expired | 1998-06-30 | 1997-07-15 | 5773854 | 08892827 |
| Method of making an integrated circuit chip having an array of logic gates | United States of America | Expired | 1997-07-22 | 1996-06-11 | 5650348 | 08665016 |
| Layout configuration for an integrated circuit gate array | United States of America | Expired | 1997-08-19 | 1995-06-07 | 5659189 | 08473543 |
| Virtual data representation through selective bidirectional translation | United States of America | Lapsed | 2012-04-10 | 2008-08-29 | 8156454 | 12201575 |
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| Integrated circuit device having a switched routing network | United States of America | Expired | 1999-04-27 | 1997-01-13 | 5898677 | 08782585 |
| High-speed internal interconnection technique for integrated circuits that reduces the number of signal lines through multiplexing | United States of America | Expired | 1997-03-25 | 1994-08-24 | 5615126 | 08294973 |
| Intelligent Timing Analysis and Constraint Generation GUI | United States of America | Lapsed | 2013-09-17 | 2009-02-19 | 8539407 | 12388741 |
| Intelligent Timing Analysis and Constraint Generation GUI | United States of America | Abandoned | 2014-10-14 | 2013-08-27 | 8863053 | 14010842 |
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| Method and apparatus for computing minimum wirelength position (MWP) for cell in cell placement for integrated circuit chip | United States of America | Expired | 1999-01-12 | 1996-08-01 | 5859781 | 08690942 |
| Method And Apparatus For Computing Minimum Wirelength Position (MWP) For Cell In Cell Placement For Integrated Circuit Chip | United States of America | Abandoned | | 1994-09-13 | | 08305217 |
| Cell placement alteration apparatus for integrated circuit chip physical design automation system | United States of America | Expired | 1998-08-11 | 1996-09-17 | 5793644 | 08724025 |
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| Advanced modular cell placement system with overlap remover with minimal noise | United States of America | Expired | 2001-04-24 | 2000-02-14 | 6223332 | 09503691 |
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| Language and templates for use in the design of semiconductor products | United States of America | Lapsed | 2008-07-22 | 2004-12-20 | 7404156 | 11017017 |
| Rules and directives for validating correct data used in the design of semiconductor products | United States of America | Granted | 2011-05-17 | 2008-05-15 | 7945878 | 12120965 |
| Guided capture, creation, and seamless integration with scalable complexity of a clock specification into a design flow of an integrated circuit | United States of America | Lapsed | 2007-10-30 | 2004-12-31 | 7290224 | 11027266 |
| Rules and directives for validating correct data used in the design of semiconductor products | United States of America | Lapsed | 2008-07-08 | 2004-12-20 | 7398492 | 11017015 |
| Method of Automating Place and Route Corrections for an Integrated Circuit Design from Physical Design Validation | United States of America | Abandoned | | 2004-10-27 | | 10975570 |
| Method of automating place and route corrections for an integrated circuit design from physical design validation | United States of America | Granted | 2007-11-27 | 2004-10-29 | 7302654 | 10977386 |
| Automation of Tie Cell Insertion, Optimization and Replacement by Scan Flip-Flops to Increase Fault Coverage | United States of America | Lapsed | 2013-10-29 | 2012-04-09 | 8572543 | 13442099 |
| Automation of Tie Cell Insertion, Optimization and Replacement by Scan Flip-Flops to Increase Fault Coverage | United States of America | Lapsed | 2009-06-09 | 2005-12-19 | 7546568 | 11311515 |
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| Generation of an Extracted Timing Model File | United States of America | Granted | 2012-05-15 | 2010-01-28 | 8181138 | 12695396 |
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| Method and Apparatus For Balancing Signal Delay Skew | United States of America | Lapsed | 2012-08-07 | 2011-06-30 | 8239813 | 13173855 |
| Method and computer program for generating grounded shielding wires for signal wiring | United States of America | Lapsed | 2013-08-20 | 2012-07-09 | 8516425 | 13544632 |
| A Skew Management Methodology for Highly Skew Sensitive Applications | United States of America | Granted | 2011-08-09 | 2008-01-17 | 7996804 | 12015925 |
| Method And System For Outputting A Sequence Of Commands And Data Described By A Flowchart | United States of America | Granted | 2011-08-23 | 2008-12-09 | 8006209 | 12315998 |
| Method and system for outputting a sequence of commands and data described by a flowchart | United States of America | Granted | 2008-12-30 | 2005-10-27 | 7472358 | 11260517 |
| Method of Selecting Cells in Logic Restructuring | United States of America | Lapsed | 2009-02-24 | 2006-10-20 | 7496870 | 11551573 |
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| Optical proximity correction method and apparatus | United States of America | Expired | 1998-03-03 | 1996-02-27 | 5723233 | 08607365 |
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| Sequential tester for longest prefix search engines | United States of America | Granted | 2007-04-03 | 2003-03-13 | 7200785 | 10387988 |
| Sequential Tester for Longest Prefix Search Engines | United States of America | Lapsed | 2009-06-16 | 2007-02-13 | 7548844 | 11706943 |
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| Method of generating test patterns to efficiently screen inline resistance delay defects in complex asics | United States of America | Lapsed | 2008-07-01 | 2007-03-07 | 7395478 | 11682914 |
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| Method of clock buffer partitioning to minimize clock skew for an integrated circuit design | United States of America | Granted | 2002-12-31 | 2001-06-04 | 6502222 | 09875314 |
| Microelectronic integrated circuit including triangular semiconductor "OR" gate devices | United States of America | Expired | 1997-08-05 | 1995-12-06 | 5654563 | 08567894 |
| Microelectronic Integrated Circuit Including Triangular Semiconductor "Or" Gate Circuit | United States of America | Abandoned | | 1995-05-10 | | 08438605 |
| Domino scan architecture and domino scan flip-flop for the testing of domino and hybrid CMOS circuits | United States of America | Expired | 2000-08-22 | 1997-10-08 | 6108805 | 08947271 |
| Domino scan architecture and domino scan flip-flop for the testing of domino and hybrid CMOS circuits | United States of America | Expired | 1999-02-02 | 1996-05-29 | 5867036 | 08655438 |
| Peripheral partitioning and tree decomposition for partial scan | United States of America | Granted | 2004-05-04 | 2000-05-10 | 6732310 | 09568049 |
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| Flip-chip integrated circuit routing to I/O devices | United States of America | Granted | 2004-01-06 | 2001-01-19 | 6674166 | 09765827 |
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| Method of analyzing static current test vectors for semiconductor integrated circuits | United States of America | Lapsed | 2004-02-17 | 2001-06-12 | 6694495 | 09879506 |
| Checking Validity of Memory Addressing in IDDQ Tools | United States of America | Expired | | 2000-09-28 | | 60236903 |
| Automatic method and system for instantiating built-in-test (BIST) modules in ASIC memory designs | United States of America | Lapsed | 2005-08-16 | 2001-10-15 | 6931606 | 09978141 |
| Automatic method and system for instantiating built-in-test (BIST) modules in ASIC memory designs | United States of America | Granted | 2006-11-21 | 2005-04-14 | 7139991 | 11107585 |
| Optimal Timing Schedule | United States of America | Abandoned | | 2001-01-08 | | 09756561 |
| Optimal clock timing schedule for an integrated circuit | United States of America | Granted | 2003-09-02 | 2001-06-12 | 6615397 | 09879380 |
| Digital gaussian noise simulator | United States of America | Granted | 2007-08-28 | 2003-05-05 | 7263470 | 10429312 |
| Digital Gaussian Noise Simulator | United States of America | Lapsed | 2010-10-26 | 2007-06-06 | 7822099 | 11758975 |
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| Novel Solution for Low Cost, Speedy Probe Cards | United States of America | Abandoned | | 2003-10-23 | | 10692110 |
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| Gate array layout to accommodate multi-angle ion implantation | United States of America | Fypired | 1999-08-10 | 1997-04-73 | 586385 | 08839103 |
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| Optimization processing for integrated circuit physical design automation system using optimally switched cost function computations | United States of America | Expired | 1998-04-28 | 1996-02-13 | 5745363 | 08600588 |
| Method for producing integrated circuit chip having optimized cell placement | United States of America | Expired | 1998-07-14 | 1995-11-13 | 5781439 | 08558165 |
| Simultaneous placement and routing (SPAR) method for integrated circuit physical design automation system | United States of America | Expired | 1998-04-21 | 1996-02-21 | 5742510 | 08604181 |
| Method of cell placement for an integrated circuit chip comprising chaotic placement and moving windows | United States of America | Expired | 1999-05-11 | 1997-05-23 | 5903461 | 08862791 |
| Computer implemented method for producing optimized cell placement for integrated circiut chip | United States of America | Expired | 1997-06-03 | 1995-11-13 | 5636125 | 08559206 |
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| Enhanced Method Of Optimizing Multiplex Structures And Multiplex Control Structures In RTL Code | United States of America | Lapsed | 2009-09-22 | 2006-07-28 | 7594201 | 11460680 |
| Method of optimizing RTL code for multiplex structures | United States of America | Lapsed | 2006-08-01 | 2004-05-12 | 7086015 | 10844664 |
| Method for estimating routability and congestion in a cell placement fo integrated circuit chip | United States of America | Expired | 1998-07-21 | 1996-12-20 | 5784289 | 08774281 |
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| Flexible Integrated Circuit Design | United States of America | Abandoned | | 1992-10-07 | | 07957672 |
| Flexible design system | United States of America | Expired | 1997-09-09 | 1992-11-23 | 5666289 | 07980492 |
| Method of generating test patterns to efficiently screen inline resistance delay defects in complex ASICs | United States of America | Granted | 2007-05-08 | 2004-07-27 | 7216280 | 10900224 |
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| Semiconductor bond pads | United States of America | Expired | 1994-02-08 | 1992-11-30 | 5284797 | 07984206 |
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| Composite bond pads for semiconductor devices | United States of America | | 1993-09-28 | 1992-09-18 | 5248903 | 07947854 |
| Ball Bump Array Semiconductor Packages | United States of America | Abandoned | | 1995-02-01 | | 08382147 |
| Ball Bump Array Semiconductor Packages | United States of America | Abandoned | | 1992-07-21 | | 07917894 |
| Optically transmissive preformed planar structures | United States of America | Expired | 1998-11-10 | 1996-07-15 | 5834799 | 08679949 |
| Optically Transmissive Preformed Planar Structures | United States of America | Abandoned | | 1993-08-12 | | 08105269 |
| Process for solder ball interconnecting a semiconductor device to a substrate using a noble metal foil embedded interposer substrate | United States of America | Expired | 1996-04-02 | 1993-08-12 | 5504035 | 08105547 |
| Manufacturing | United States of America | Abandoned | | 1989-08-28 | | 07400572 |
| Method And Apparatus For Isolation Of Flux Materials In Flip-Chip | | | | | | |
| Ball Bump Array Semiconductor Packages | United States of America | Abandoned | | 1992-09-01 | | 07938690 |
| Floorplanning Techniques Using Multi-Partitioning Based On A Partitions Cost Factor For Non-Square Shaped Partitions | United States of America | Abandoned | | 1993-02-10 | | 08015947 |
| Semiconductor Packaging Technique Yielding Increased Inner Lead Count For A Given Die-Receiving Area | United States of America | Abandoned | | 1994-07-01 | | 08270123 |
| Multi-chip semiconductor arrangements using flip chip dies | United States of America | Expired | 1995-03-21 | 1992-11-12 | 5399898 | 07975185 |
| Overmolded Semiconductor Package | United States of America | Abandoned | | 1996-07-29 | | 08688148 |
| High-density bond pad layout arrangements for semiconductor dies, and connecting to the bond pads | United States of America | Expired | 1997-06-03 | 1995-04-28 | 5635424 | 08430399 |
| Technique of increasing bond pad density on a semiconductor die | United States of America | Expired | 1994-04-05 | 1992-08-25 | 5300815 | 07935449 |
| Seglen Method of Estimating Porosity of Tera Gates | United States of America | Expired | | 2000-11-30 | | 60250482 |
| Method for estimating cell porosity of hardmacs | United States of America | Granted | 2003-08-26 | 2001-06-29 | 6611951 | 09895668 |
| Infrastructure | United States of America | Lapsed | 2012-07-24 | 2008-09-18 | 8230263 | 12212736 |
| Automated Specification Rased Functional Test Generation | Office of Afficial | Expired | | 2007-03-13 | | 009/3330 |
| Automated Specification Based Functional Test Generation | Thital Ctate of America | | | 7007 00 10 | | 60073550 |
| Off-grid metal layer utilization | United States of America | Granted | 2002-01-15 | 2000-10-20 | 6338972 | 09693014 |
| Off-grid metal layer utilization | United States of America | Granted | 2001-01-16 | 1998-10-30 | 6174742 | 09183292 |
| Decoder Using a Memory for Storing State Metrics Implementing a Decoder Trellis | United States of America | Granted | 2011-03-01 | 2008-12-16 | 7900184 | 12336104 |
| Metacors: Design and Optimization Techniques | United States of America | Abandoned | | 1900-01-01 | | 60383890 |
| Metacores: design and optimization techniques | United States of America | Lapsed | 2006-03-21 | 2002-11-26 | 7017126 | 10304289 |
| Decoder using a memory for storing state metrics implementing a decoder trellis | United States of America | Lapsed | 2008-12-16 | 2005-11-03 | 7467359 | 11266687 |
| Accurate Pin-Based Memory Power Model Using Arc-Based Characterization | United States of America | Lapsed | 2009-12-29 | 2008-05-01 | 7640152 | 12150846 |
| Accurate pin-based memory power model using arc-based characterization | United States of America | Lapsed | 2008-05-20 | 2004-09-09 | 7376541 | 10937049 |
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| Apparatus for isolation of flux materials in flip-chip manufacturing | United States of America | Expired | 1992-05-05 | 1990-08-30 | 5111279 | 07576182 |
| Floorplanning technique using multi-partitioning based on a partition cost factor for non-square shaped partitions | United States of America | Expired | 1996-07-02 | 1995-04-03 | 5532934 | 08416457 |
| Method of laying out bond pads on a semiconductor die | United States of America | Expired | 1995-08-15 | 1994-05-31 | 5441917 | 08251058 |
| Semiconductor packaging technique yielding increased inner lead count for a given die-receiving area | United States of America | Expired | 1994-07-12 | 1992-08-21 | 5329157 | 07933430 |
| Method of assembling ball bump grid array semiconductor packages | United States of America | Expired | 1998-03-24 | 1996-06-14 | 5729894 | 08664146 |
| Method of increasing the layout efficiency of dies on a wafer, and increasing the ratio of I/O area to active area per die | United States of America | Expired | 1994-08-23 | 1992-11-18 | 5341024 | 07978483 |
| Method of increasing the layout efficiency of dies on a wafer and increasing the ratio of I/O area to active area per die | United States of America | Expired | 1994-08-23 | 1992-07-17 | 5340772 | 07916328 |
| Partially-molded, PCB chip carrier package for certain non-square die shapes | United States of America | Expired | 1997-01-14 | 1995-05-02 | 5594626 | 08432535 |
| Preformed planar structures employing embedded conductors | United States of America | Expired | 1994-09-13 | 1993-08-12 | 5347162 | 08105838 |
| Preformed planar structures for semiconductor device assemblies | United States of America | Expired | 1996-10-29 | 1995-04-25 | 5569963 | 08428323 |
| Method and apparatus for isolation of flux materials in flip-chip manufacturing | United States of America | Expired | 1992-12-01 | 1991-10-11 | 5168346 | 07775009 |
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| Overmolded semiconductor package | United States of America | Expired | 1996-09-17 | 1995-04-27 | 5557150 | 08429605 |
| Overmolded Semiconductor Package | United States of America | Abandoned | | 1994-10-28 | | 08331263 |
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| Method And Apparatus For Isolation Of Flux Materials In Flip-Chip Manufacturing | United States of America | Expired | 1995-05-02 | 1994-02-10 | 5410805 | 08194241 |
| Non-Square Die For Integrated Circuit And Systems Containing The Same | United States of America | Expired | 1998-04-28 | 1900-01-01 | 5744856 | 08476431 |
| Mounting And Connecting Non-Square Semiconductor Dies | United States of America | Abandoned | | 1992-12-18 | | 07993188 |
| Semiconductor device assembly techniques using preformed planar structures | United States of America | Expired | 1998-10-13 | 1995-06-05 | 5821624 | 08470945 |
| Semiconductor bond pad structure and increased bond pad count per die | United States of America | Expired | 1996-10-15 | 1995-02-10 | 5565385 | 08387154 |
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| Method and apparatus for interim in-situ testing of an electronic system with an inchoate ASIC | United States of America | Expired | 1997-05-13 | 1992-08-31 | 5629876 | 07937643 |
| Low profile variable width input/output cells | United States of America | Expired | 1998-07-07 | 1997-04-21 | 5777354 | 08837570 |
| Method for designing low profile variable width input/output cells | United States of America | Expired | 1996-09-03 | 1994-09-16 | 5552333 | 08307942 |
| Low Profile Variable Width Input/Output Cells | United States of America | Abandoned | | 1996-06-19 | | 08668084 |
| circuit physical design automation system | United States of America | Expired | 1999-02-23 | 1996-04-23 | 5875117 | 08636349 |
| Simultaneous placement and routing (CDAD) mothed for integrated | United States of America | Apandoned | | 1994-04-19 | | 08230023 |
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| Hexagonal sense cell architecture | United States of America | Expired | 1999-02-16 | 1995-08-21 | 5872380 | 08517189 |
| Tri-directional interconnect architecture for SRAM | United States of America | Expired | 1999-03-30 | 1995-08-21 | 5889329 | 08517339 |
| Microelectronic Device | United States of America | Abandoned | | 1995-08-21 | | 08517582 |
| Method For Minimizing Total Wire Length Of Interconnect In A | | | | | | |
| CAD for hexagonal architecture | United States of America | Expired | 1998-10-13 | 1995-08-21 | 5822214 | 08517171 |
| Architecture having diamond shaped or parallelogram shaped cells | United States of America | Expired | 1999-10-26 | 1995-08-21 | 5973376 | 08517406 |
| Hexagonal DRAM array | United States of America | Expired | 1998-04-21 | 1995-08-21 | 5742086 | 08517153 |
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| Directional Interconnect Routing Based On Hexagonal Geometry | United States of America | Abandoned | | 1996-07-24 | | 08685476 |
| Microelectronic Integrated Circuit Structure And Method Using Three | | | | | | |
| Hexagonal architecture with triangular shaped cells | United States of America | Expired | 1998-08-04 | 1995-08-21 | 5789770 | 08517236 |
| Triangular semiconductor or gate | United States of America | Expired | 2000-08-01 | 1995-08-21 | 6097073 | 08517892 |
| Hexagonal SRAM architecture | United States of America | Expired | 1998-09-01 | 1995-08-21 | 5801422 | 08517266 |
| Method And Apparatus for Reducing Intermetal Capacitance in a Microelectronic Device | United States of America | Abandoned | | 1995-08-21 | | 08517054 |
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| Partially-molded, PCB chip carrier package | United States of America | Expired | 1993-11-16 | 1992-02-07 | 5262927 | 07834182 |
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| PatentNo | OVER-CORE WINDOW ON A CHIP-LEVEL ROUTING LAYER | United States of America | Lapsed | 2012-11-27 | 2010-06-01 | 8321826 | 12791260 |
| PatentNo | LOGIC IN THE CHIP-LEVEL IMPLEMENTATION PROCESS THROUGH AN | | | | | | |
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| PatentNo FiledDate GrantDate Status Country 41 5640337 1996-08-13 1997-06-17 Expired United States of America 1996-02-09 Abandoned United States of America | Method and apparatus for interim. in-situ testing of an electronic system | | | | | | |
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|---|--------------------------|-----------|------------|------------|----------|----------|
| System and Method for Coevolutionary Circuit Design | United States of America | Abandoned | | 2005-02-10 | | 11054879 |
| I/O planning with lock and insertion features | United States of America | Lapsed | 2009-06-02 | 2005-04-27 | 7543261 | 11115798 |
| I/O planning with lock and insertion features | United States of America | Granted | 2012-01-17 | 2009-04-30 | 8099708 | 12432996 |
| Mixed LVR and HVR reticle set design for the processing of gate arrays, embedded arrays and rapid chip products | United States of America | Lapsed | 2006-06-06 | 2005-02-08 | 7057261 | 11053505 |
| Mixed LVR and HVR reticle set design for the processing of gate arrays, embedded arrays and rapid chip products | United States of America | Lapsed | 2005-05-31 | 2003-10-31 | 6900075 | 10699276 |
| Special Engineering Change Order Cells | United States of America | Lapsed | 2009-12-15 | 2004-07-22 | 7634748 | 10897655 |
| Special Engineering Change Order Cells | United States of America | Lapsed | 2012-12-11 | 2009-10-29 | 8332801 | 12608469 |
| Dual source lithography for direct write application | United States of America | | 2006-04-04 | 2005-03-07 | 7023530 | 11075239 |
| Dual source lithography for direct write application | United States of America | Lapsed | 2005-05-17 | 2002-09-17 | 6894762 | 10246286 |
| Disabling unused IO resources in platform-based integrated circuits | United States of America | Lapsed | 2008-09-30 | 2004-08-02 | 7430730 | 10909603 |
| Disabling unused IO resources in platform-based integrated circuits | United States of America | Lapsed | 2012-04-03 | 2008-08-22 | 8151237 | 12229446 |
| Timing Violation Debugging Inside Place and Route Tool | United States of America | Lapsed | 2013-11-12 | 2010-05-13 | 8584068 | 12779312 |
| Timing Violation debugging inside Place and Route Tool | United States of America | Lapsed | 2010-06-29 | 2007-11-28 | 7747975 | 11946243 |
| Timing violation debugging inside place and route tool | United States of America | Lapsed | 2008-01-29 | 2005-08-31 | 7325215 | 11216918 |
| Intelligent crosstalk delay estimator for integrated circuit design flow | United States of America | Lapsed | 2006-05-09 | 2003-06-09 | 7043708 | 10458547 |
| Method of finding critical nets in an integrated circuit design | United States of America | Lapsed | 2006-09-12 | 2004-08-23 | 7107558 | 10924531 |
| PROCESS OF USING THE SAME | United States of America | Lapsed | 2013-07-09 | 2009-10-09 | 8484608 | 12576775 |
| BASE PLATFORMS WITH COMBINED ASIC AND FPGA FEATURES AND | | | | | | |
| PROCESS OF USING THE SAME | United States of America | Lapsed | 2009-11-17 | 2005-03-14 | 7620924 | 11079439 |
| BASE PLATFORMS WITH COMBINED ASIC AND FPGA FEATURES AND | | | | | | |
| Method for evaluating logic functions by logic circuits having optimized number of and/or switches | United States of America | Lapsed | 2008-02-05 | 2005-02-10 | 7328423 | 11055752 |
| Method for evaluating logic functions by logic circuits having optimized number of and/or switches | United States of America | Lapsed | 2005-05-31 | 2003-03-05 | 6901573 | 10382036 |
| Digitally Obtaining Contours of Fabricated Polygons | United States of America | Granted | 2010-11-02 | 2005-07-15 | 7827509 | 11182615 |
| Digitally Obtaining Contours of Fabricated Polygons | United States of America | Lapsed | 2013-09-03 | 2010-09-24 | 8527912 | 12890336 |
| relative segmentation | United States of America | Granted | 2003-03-11 | 2000-11-14 | 6532585 | 09714370 |
| Method and apparatus for application of proximity correction with | | | | | | |
| Method of proximity correction with relative segmentation | United States of America | Granted | 2001-01-16 | 1998-03-03 | 6174630 | 09034550 |
| Automatic calibration of a masking process simulator | United States of America | | 2005-03-15 | 2004-04-20 | 6868355 | 10829408 |
| Automatic calibration of a masking process simulator | United States of America | Lapsed | 2004-07-27 | 2002-11-26 | 6768958 | 10305673 |
| for use in an optical direct write lithography process | United States of America | Granted | 2007-03-13 | 2004-11-19 | 7189498 | 10993603 |
| Process and apparatus for generating a strong phase shift optical pattern | | | | | | |
| Strong Phase Shift for Maskless Lithography | United States of America | _ | | 2004-01-08 | | 60535586 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| System and method for performing optical proximity correction on the interface between optical proximity corrected cells | United States of America | Expired | 2002-07-23 | 1997-09-29 | 6425117 | 08937296 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| macrocell libraries | United States of America | Expired | 1997-10-28 | 1995-03-06 | 5682323 | 08401099 |
| System and method for performing optical proximity correction on | | | | | | |
| Static timing and risk analysis tool | United States of America | Granted | 2007-02-20 | 2005-01-03 | 7181713 | 11028403 |
| Static timing analysis and performance diagnostic display tool | United States of America | Lapsed | 2005-02-01 | 2002-08-28 | 6851098 | 10232423 |
| Suite of tools to design integrated circuits | United States of America | Lapsed | 2008-09-30 | 2005-06-18 | 7430725 | 11156319 |
| Simplified process to design integrated circuits | United States of America | Lapsed | 2006-05-30 | 2002-12-31 | 7055113 | 10335360 |
| Extensible IO testing implementation | United States of America | Lapsed | 2007-10-16 | 2003-04-16 | 7284211 | 10417007 |
| Flexible and extensible implementation of sharing test pins in ASIC | United States of America | Lapsed | 2006-05-16 | 2003-05-19 | 7047470 | 10441000 |
| Apparatus and Method for Analyzing Circuits | United States of America | Expired | 1996-07-16 | 1994-06-30 | 5537329 | 08269230 |
| Modeling Of Large Linear Subcircuits | United States of America | Expired | 1997-11-18 | 1995-06-09 | 5689685 | 08489270 |
| Apparatus And Method For Analyzing Circuits Using Reduced-Order | | | | | | |
| foundry processes | United States of America | Lapsed | 2006-07-11 | 2004-01-29 | 7076746 | 10768558 |
| Method and apparatus for mapping platform-based design to multiple | | | | | | |
| Foundry Processes | United States of America | Abandoned | | 2004-01-29 | | 10768588 |
| Method and Apparatus for Mapping Platform-based Design to Multiple | | | | | | |
| foundry processes | United States of America | Lapsed | 2006-05-23 | 2003-08-04 | 7051297 | 10634634 |
| Method and apparatus for mapping platform-based design to multiple | | | | | | |
| Parameter Extraction | United States of America | Expired | 2000-05-16 | 1997-08-01 | 6064808 | 08904488 |
| Components In Integrated Circuits And Equivalent Structures By Efficient | | | | | | |
| Method And Apparatus For Designing Interconnections And Passive | | | | | | |
| Efficient Three Dimensional Extraction | United States of America | Expired | 2000-04-18 | 1998-07-16 | 6051027 | 09116158 |
| Quadrature Solutions For 3D Capacitance Extraction | United States of America | Expired | 2001-11-06 | 1998-11-06 | 6314545 | 09187505 |
| Optimizing IC clock structures by minimizing clock uncertainty | United States of America | Lapsed | 2008-04-08 | 2006-04-11 | 7356785 | 11402146 |
| Optimizing IC clock structures by minimizing clock uncertainty | United States of America | Lapsed | 2006-08-22 | 2003-07-10 | 7096442 | 10616623 |
| Architecture for a sea of platforms | United States of America | Granted | 2003-10-28 | 2002-01-10 | 6640333 | 10044781 |
| Architecture for a sea of platforms | United States of America | Granted | 2006-06-06 | 2003-07-23 | 7058906 | 10626825 |
| architecture | United States of America | Lapsed | 2006-09-26 | 2004-03-25 | 7114133 | 10809939 |
| Broken symmetry for optimization of resource fabric in a sea-of-platform | | | | | | |
| Extended Instruction Sets In A Platform Architecture | United States of America | Abandoned | | 1900-01-01 | | 10135189 |
| ASICs | United States of America | Granted | 2007-05-01 | 2003-12-02 | 7213224 | 10725638 |
| Customizable development and demonstration platform for structured | | | | | | |
| ASICs | United States of America | Lapsed | 2010-02-16 | 2007-03-15 | 7665058 | 11724663 |
| Customizable Development and Demonstration Platform for Structured | | | | | | |
| Method for post-OPC multi layer overlay quality inspection | United States of America | Lapsed | 2008-05-20 | 2004-12-14 | 7376260 | 11011384 |
| Quality measurement of an aerial image | United States of America | Lapsed | 2006-04-25 | 2002-05-22 | 7035446 | 10155620 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Systematic, Normalized Metric For Analyzing And Comparing Optimization Techniques For Intergrated Circuits Employing Voltage Scaling And Integrated Circuits Designed Thereby | United States of America | Abandoned | 2012-10-02 | 2009-02-03 | 8781766 | 12365010 |
|---|--------------------------|-----------|------------|--|-------------|----------|
| A Systematic, Normalized Metric For Analyzing And Comparing Optimization Techniques For Intergrated Circuits Employing Voltage Scaling And Integrated Circuits Designed Thereby | United States of America | Abandoned | | 2012-08-30 | | 13599549 |
| Method of automatically generating schematic and waveform diagrams for isolating faults from multiple failing paths in a circuit using input signal predictors and transition times | United States of America | Lapsed | 2003-12-30 | 2000-10-06 | 6671846 | 09684770 |
| Method of automatically generating schematic and waveform diagrams for relevant logic cells of a circuit using input signal predictors and transition times | United States of America | Granted | 2003-09-23 | 2000-06-20 | 6625770 | 09597433 |
| Conditional Path Delay SDF Generation | United States of America | Abandoned | | 2000-09-29 | | 60237737 |
| Generating standard delay format files with conditional path delay for designing integrated circuits | United States of America | Granted | 2002-09-17 | 2001-06-12 | 6453451 | 09880607 |
| Method for repairing an ASIC memory with redundancy row and input/output lines | United States of America | Expired | 2000-05-16 | 1998-03-30 | 6065134 | 09052043 |
| Method For Repairing An Asic Memory With Redundancy Row And Input/Output Lines | United States of America | Abandoned | | 1996-02-07 | | 08598155 |
| Methods For Measurement And Prediction Of Hold-Time And Exceeding Hold Time Limits Due To Cells With Tied Input Pins | United States of America | Lapsed | 2008-09-09 | 2006-03-16 | 7424693 | 11377778 |
| Methods For Measurement And Prediction Of Hold-Time And Exceeding Hold Time Limits Due To Cells With Tied Input Pins | United States of America | Granted | 2013-06-18 | 2008-08-07 | 8468478 | 12187464 |
| Generalized BIST For Multiport Memories | United States of America | Granted | 2012-06-12 | 2007-07-11 | 8201032 | 11775956 |
| Generalized BIST For Multiport Memories | United States of America | Abandoned | | 2004-10-27 | | 10974450 |
| Method of analyzing static current test vectors with reduced file sizes for semiconductor integrated circuits | United States of America | Granted | 2002-09-10 | 2001-06-12 | 6449751 | 09879417 |
| Method for Reducing VCD File Size For IDDQ Testing | United States of America | Expired | | 2000-08-22 | | 60227132 |
| Process for fast cell placement in integrated circuit design | United States of America | Lapsed | 2004-03-09 | 2001-06-12 | 6704915 | 09879643 |
| Process For Fast Cell Placement In Integrated Circuit Design | United States of America | Abandoned | | 2001-01-08 | | 09756568 |
| System and method for optimizing an integrated circuit design | United States of America | Granted | 2004-06-15 | 2001-10-30 | 6751783 | 10021696 |
| System and method for optimizing an integrated circuit design | United States of America | Lapsed | 2008-07-08 | 2004-01-30 | 7398501 | 10769510 |
| Method and apparatus for adaptive timing optimization of an integrated circuit design | United States of America | Lapsed | 2006-03-28 | 2001-09-26 | 7020589 | 09964030 |
| An Integrated Adaptive Timing Optimization Technique | United States of America | Abandoned | | 1900-01-01 | | 60236589 |
| Delay Estimation for Virtual Tree Based Netlist Model | United States of America | Abandoned | | 1900-01-01 | | 60236953 |
| Virtual tree-based netlist model and method of delay estimation for an integrated circuit design | United States of America | Granted | 2003-11-04 | 2001-09-26 | 6643832 | 09964011 |
| | Codility | irri | 0.000 | i de la companya de l | 8 6 6 6 6 6 | |

| -12-06 Lapsed United States of America simulations -03-02 Lapsed United States of America Optical and etch proximity correction -10-14 Granted United States of America Delay/load estimation for use in integrated circuit design | L | | • | | |
|--|---|------------|------------|----------|----------|
| Lapsed United States of America Simula Lapsed United States of America Optica | | 2003-10-14 | 2000-12-12 | 6634014 | 09735255 |
| Lapsed United States of America simula | | 2004-03-02 | 2001-08-13 | 6701511 | 09928471 |
| impedance bullet development, verification and system level | | 2005-12-06 | 2001-08-21 | 6973421 | 09934051 |
| BZFLASH subcircuit to dynamically supply BZ codes for controlled | | | | | |
| -07-09 Granted United States of America Silicon verification with embedded testbenches | | 2002-07-09 | 1999-09-22 | 6417562 | 09400686 |
| -04-01 Granted United States of America Capacitance estimation | | 2003-04-01 | 1999-11-24 | 6542834 | 09449324 |
| -07-04 Expired United States of America Advanced modular cell placement system with sinusoidal optimization | | 2000-07-04 | 1996-06-28 | 6085032 | 08671659 |
| -11-09 Expired United States of America Virtual monitor debugging method and apparatus | | 1999-11-09 | 1996-11-12 | 5983017 | 08745526 |
| -06-14 Lapsed United States of America crosstalk | | 2005-06-14 | 2001-10-02 | 6907586 | 09968009 |
| -07-04 Granted United States of America electronic circuit designs | | 2000-07-04 | 1998-05-05 | 6083271 | 09072566 |
| -03-25 Expired United States of America Clock skew insensitive scan chain reordering | | 2003-03-25 | 1996-05-22 | 6539509 | 08650248 |
| -11-30 Expired United States of America Method for capturing ASIC I/O pin data for tester compatibility analysis | | 1999-11-30 | 1996-12-23 | 5995740 | 08773469 |
| -04-16 Granted United States of America Staged Scenario Generation | | 2013-04-16 | 2011-06-01 | 8423933 | 13150607 |
| Abandoned United States of America Staged Scenario Generation | ᆮ | | 2012-10-23 | | 13658336 |
| -07-05 Granted United States of America Staged Scenario Generation | | 2011-07-05 | 2007-12-03 | 7975248 | 11949187 |
| Abandoned United States of America AUTOMATION TOOLS | | | 2006-02-27 | | 11364142 |
| Granted United States of America | | 2011-06-07 | 2008-05-09 | 7958473 | 12117760 |
| -05-15 Granted United States of America Inversion Circuit Timing Analysis Incorporating The Effects Of Temperature Inversion | | 2012-05-15 | 2008-10-14 | 8181144 | 12251088 |
| -02-04 Lapsed United States of America Inversion | | 2014-02-04 | 2012-04-23 | 8645888 | 13453289 |
| Abandoned United States of America Inversion Circuit Timing Analysis Incorporating The Effects Of Temperature | | | 2013-11-29 | | 14093189 |
| -11-19 Lapsed United States of America Total Power Optimization for a Logic Integrated Circuit | | 2013-11-19 | 2011-05-09 | 8589853 | 13103461 |
| Abandoned United States of America Total Power Optimization for a Logic Integrated Circuit | | | 2013-10-14 | | 14053194 |
| Abandoned United States of America Circuit and Methods for Efficient Clock and Data Delay Configuration for Faster Timing Closure | | | 2013-10-18 | | 14057441 |
| -11-26 Lapsed United States of America Faster Timing Closure | | 2013-11-26 | 2012-09-26 | 8595668 | 13627054 |
| tDate Status Country Title | | GrantDate | FiledDate | PatentNo | AppNo |

| VDHL/Verilog expertise and gate synthesis automation system | United States of America | Granted | 2001-09-11 | 1998-02-20 | 6289498 | 09027422 |
|---|--------------------------|---------|------------|------------|----------|------------|
| Internal clock handling in synthesis script | United States of America | Granted | 2001-01-09 | 1998-02-20 | 6173435 | 09027423 |
| Standard cell integrated circuit layout definition having functionally uncommitted base cells | United States of America | Granted | 2000-07-25 | 1998-02-26 | 6093214 | 09031956 |
| Automatic ranging apparatus and method for precise integrated circuit current measurements | United States of America | Expired | 2000-08-08 | 1997-10-30 | 6101458 | 08961163 |
| PLD/ASIC hybrid integrated circuit | United States of America | Granted | 2001-01-23 | 1998-03-30 | 6178541 | 09050824 |
| Netlist analysis tool by degree of conformity | United States of America | Granted | 2001-09-11 | 1998-02-20 | 6289491 | 09027501 |
| Buffering tree analysis in mapped design | United States of America | Granted | 2001-03-20 | 1998-02-20 | 6205572 | 09027399 |
| Automatic synthesis script generation for synopsys design compiler | United States of America | Lapsed | 2004-12-28 | 1998-02-20 | 6836877 | 09026790 |
| Low voltage screen for improving the fault coverage of integrated circuit production test programs | United States of America | Granted | 2000-10-03 | 1998-06-16 | 6128757 | 09098172 |
| Utilizing a technology-independent system description incorporating a metal layer dependent attribute | United States of America | Lapsed | 2004-02-03 | 1998-05-26 | 6687661 | 09085143 |
| Method of accessing the generic netlist created by synopsys design compilier | United States of America | Granted | 2001-07-17 | 1998-02-20 | 6263483 | 09027512 |
| Clock distribution network planning and method therefor | United States of America | Granted | 2001-10-16 | 1998-06-18 | 6305001 | 09099287 |
| Integrated circuit design with delayed cell selection | United States of America | Granted | 2001-08-14 | 1998-10-30 | 6275973 | 09183637 |
| Flexible width cell layout architecture | United States of America | Granted | 2002-05-07 | 1999-10-01 | 6385761 | 09410405 |
| Method and apparatus for netlist filtering and cell placement | United States of America | Granted | 2001-06-05 | 1998-03-13 | 6243849 | 09042230 |
| Method and apparatus for zero skew routing from a fixed H trunk | United States of America | Granted | 2001-12-04 | 1998-05-05 | 6327696 | 09072570 |
| Physical design automation system and process for designing integrated circuit chips using multiway partitioning with constraints | United States of America | Granted | 2000-10-17 | 1997-12-16 | 6134702 | 08991419 |
| Optical Proximity Correction Method And Apparatus | Japan | Granted | 1999-11-12 | 1998-04-23 | 3001855 | 10153504 |
| Hybrid aerial image simulation | United States of America | Granted | 2001-01-09 | 1999-01-20 | 6171731 | 09233885 |
| Method for I/O device layout during integrated circuit design | United States of America | Granted | 2000-05-02 | 1998-04-17 | 6057169 | 09062254 |
| Wire routing optimization | United States of America | Granted | 2002-06-25 | 1998-07-22 | 6412102 | 09120617 |
| Geometric Aerial Image Simulator. | Japan | Lapsed | 2010-09-03 | 2000-01-20 | 4580134 | 2001554268 |
| Poly routing for chip interconnects with minimal impact on chip performance | United States of America | Granted | 2001-05-29 | 1998-07-14 | 6240542 | 09115464 |
| RTL code optimization for resource sharing structures | United States of America | Granted | 2002-08-20 | 2001-05-30 | 6438730 | 09866661 |
| Circuit modeling | United States of America | Granted | 2002-12-31 | 2001-05-02 | 6502230 | 09847460 |
| Metal layer assignment | United States of America | Granted | 2001-01-30 | 1998-07-16 | 6182272 | 09118661 |
| 4 point derating scheme for propagation delay and setup/hold time computation | United States of America | Lapsed | 2004-11-16 | 2000-02-29 | 6820048 | 09515376 |
| Design system upgrade migration | United States of America | Lapsed | 2005-09-27 | 2001-07-27 | 6951017 | 09916958 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
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| Built in self repair for DRAMs using on-chip temperature sensing and heating | United States of America | Expired | 1999-09-21 | 1997-10-27 | 5956350 | 08958775 |
|--|--------------------------|---------|------------|------------|----------|----------|
| Protection of proprietary circuit designs during gate level static timing analysis | United States of America | Expired | 1999-03-23 | 1996-09-25 | 5886900 | 08719508 |
| Yield improvement techniques through layout optimization | United States of America | Expired | 1999-09-14 | 1997-03-14 | 5953518 | 08818640 |
| Computer system and method for building a hardware description language representation of control logic for a complex digital system | United States of America | Expired | 1999-11-16 | 1996-12-13 | 5987239 | 08766650 |
| Flip-flop for scan test chain | United States of America | Expired | 1999-03-23 | 1997-01-07 | 5886901 | 08779628 |
| Digital integrated circuit design system and methodology with hardware | United States of America | Expired | 2000-07-04 | 1997-08-19 | 6083269 | 08914493 |
| Integrated circuit floor plan optimization system | United States of America | Expired | 1999-04-27 | 1997-02-11 | 5898597 | 08798652 |
| Method and apparatus for horizontal congestion removal | United States of America | Expired | 2000-09-26 | 1997-08-06 | 6123736 | 08906949 |
| Functional-pattern management system for device verification | United States of America | Lapsed | 2005-11-22 | 1999-07-28 | 6968286 | 09363311 |
| System and method for representing a system level RTL design using HDL independent objects and translation to synthesizable RTL code | United States of America | Expired | 2000-10-24 | 1997-10-23 | 6135647 | 08956874 |
| Resynthesis method for significant delay reduction | United States of America | Granted | 2000-08-29 | 1998-01-21 | 6109201 | 09010395 |
| Method and apparatus for congestion driven placement | United States of America | Expired | 2000-05-30 | 1997-08-06 | 6070108 | 08906950 |
| Method and apparatus for continuous column density optimization | United States of America | Expired | 2000-06-13 | 1997-08-06 | 6075933 | 08906946 |
| Graphical user interface to integrate third party tools in power integrity analysis | United States of America | Lapsed | 2004-01-06 | 2001-10-24 | 6675363 | 10014746 |
| Parallel processing of Integrated circuit pin arrival times | United States of America | Granted | 1999-12-07 | 1997-11-05 | 6000038 | 08964784 |
| RTL back annotator | United States of America | Granted | 2002-08-27 | 2001-06-12 | 6442738 | 09879297 |
| Domino Scan Architecture And Domino Scan Flip-Flop For The Testing Of Domino And Hybrid Cmos Circuits | Japan | Lapsed | 2007-04-06 | 1997-05-27 | 3937032 | 09136971 |
| Memory-saving method and apparatus for partitioning high fanout nets | United States of America | Granted | 2000-11-28 | 1998-04-17 | 6154874 | 09062219 |
| Net routing using basis element decomposition | United States of America | Granted | 2001-06-26 | 1998-04-17 | 6253363 | 09062218 |
| Method and apparatus for hierarchical global routing descend | United States of America | Granted | 2001-01-16 | 1998-04-17 | 6175950 | 09062217 |
| Timing-driven placement method utilizing novel interconnect delay model | United States of America | Lapsed | 2005-05-31 | 1998-01-21 | 6901571 | 09010396 |
| Method For Creating And Using Design Shells For Integrated Circuit Designs | Japan | Expired | 2009-11-13 | 1997-05-07 | 4405599 | 13163097 |
| Method for designing application specific integrated circuits | United States of America | Granted | 2001-12-25 | 1998-03-30 | 6334207 | 09050823 |
| Dynamic logic element having non-invasive scan chain insertion | United States of America | Granted | 2000-05-30 | 1998-01-15 | 6070259 | 09007407 |
| Wire routing to control skew | United States of America | Granted | 2002-10-29 | 2000-05-03 | 6473891 | 09564062 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Cell placement method for microelectronic integrated circuit combining clustering, cluster placement and de-clustering | United States of America | Expired | 1997-10-28 | 1994-10-05 | 5682321 | 08318275 |
|--|--------------------------|-----------|------------|------------|----------|----------|
| Computer system and method for performing design automation in a distributed computing environment | United States of America | Expired | 1999-05-25 | 1996-11-22 | 5907494 | 08754142 |
| Driver waveform modeling with multiple effective capacitances | United States of America | Lapsed | 2005-01-18 | 2001-03-21 | 6845348 | 09814417 |
| Physical design automation system and process for designing integrated circuit chips using generalized assignment | United States of America | Expired | 1998-07-21 | 1995-09-29 | 5784287 | 08536004 |
| Method And Apparatus For Reducing Intermetal Capacitance In A Microelectronic Device | United States of America | Abandoned | | 1995-08-21 | | 08517054 |
| Method for creating and using design shells for integrated circuit designs | United States of America | Expired | 1998-12-01 | 1996-05-10 | 5844818 | 08627823 |
| Distributed computer aided design system and method | United States of America | Granted | 2002-05-28 | 1998-05-28 | 6397117 | 09085717 |
| Density driven assignment of coordinates | United States of America | Lapsed | 2003-01-28 | 2001-04-27 | 6513148 | 09844361 |
| epsilon-discrepant self-test technique | United States of America | Granted | 2002-10-15 | 2001-06-12 | 6467067 | 09879845 |
| Process, apparatus and program for transforming program language description of an IC to an RTL description | United States of America | Granted | 2002-11-26 | 2001-05-04 | 6487698 | 09849919 |
| optimization | United States of America | Expired | 1998-08-18 | 1996-03-01 | 5796625 | 08609359 |
| Physical design automation system and process for designing integrated circuit chip using simulated annealing with chessboard and jiggle | | | | | | |
| increase in resolution | United States of America | Expired | 2000-02-29 | 1996-06-28 | 6030110 | 08671651 |
| Advanced modular cell placement system with median control and | | | | | | |
| Advanced modular cell placement system with universal affinity driven discrete placement optimization | United States of America | Expired | 1998-12-01 | 1996-06-28 | 5844811 | 08671656 |
| driven optimization | United States of America | Expired | 1998-09-22 | 1996-06-28 | 5812740 | 08674605 |
| Advanced modular cell placement system with neighborhood system | | | | | | |
| Hardware system verification environment tool | United States of America | Expired | 1998-10-13 | 1996-04-02 | 5822226 | 08626773 |
| Simulation based extractor of expected waveforms for gate-level power analysis tool | United States of America | Expired | 1998-11-10 | 1996-06-11 | 5835380 | 08661888 |
| Parametrized waveform processor for gate-level power analysis tool | United States of America | Expired | 1998-06-16 | 1996-06-11 | 5768145 | 08661889 |
| Scan method for built-in-self-repair (BISR) | United States of America | Lapsed | 2005-08-09 | 2001-06-13 | 6928598 | 09880675 |
| Integrated circuit layout routing using multiprocessing | United States of America | Expired | 1999-11-09 | 1996-12-04 | 5980093 | 08760641 |
| Integrated circuit cell placement parallelization with minimal number of conflicts | United States of America | Expired | 1999-02-23 | 1997-02-11 | 5875118 | 08798653 |
| Photomask inspection method and inspection tape therefor | United States of America | Expired | 1998-09-08 | 1996-12-23 | 5804340 | 08772309 |
| Net delay optimization with ramptime violation removal | United States of America | Granted | 2003-01-14 | 2001-05-15 | 6507939 | 09858166 |
| Method and apparatus for scan chain with reduced delay penalty | United States of America | Expired | 1998-11-03 | 1997-03-17 | 5831993 | 08819856 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| Method and computer program product for detecting potential failures in an integrated circuit design after optical proximity correction | United States of America | Lapsed | 2008-10-07 | 2005-12-29 | 7434198 | 11323401 |
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| Method of control cell placement for datapath macros in integrated circuit designs | United States of America | Granted | 2003-07-01 | 2001-06-26 | 6588003 | 09892241 |
| High Performance Tiling For RRAM Memory | United States of America | Lapsed | 2010-06-15 | 2005-10-24 | 7739471 | 11256830 |
| Timing constraints methodology for enabling clock reconvergence pessimism removal in extracted timing models | United States of America | Lapsed | 2008-07-29 | 2005-12-06 | 7406669 | 11295351 |
| Method and apparatus for tiling memories in integrated circuit layout | United States of America | Lapsed | 2008-06-17 | 2005-11-16 | 7389484 | 11280879 |
| Advanced Modular Cell Placement System With Affinity Driven Discrete Placement Optimization | Adva Germany (Federal Republic Place | Expired | 2009-10-14 | 1997-06-26 | 69739620.7 | 979322989 |
| Method and Apparatus for Fixing Best Case Hold Time Violations in an Integrated Circuit Design | United States of America | Lapsed | 2009-09-15 | 2006-08-24 | 7590957 | 11509370 |
| Method and apparatus for minimization of process defects while routing | United States of America | Granted | 2001-05-08 | 1998-04-17 | 6230306 | 09062310 |
| Device for avoiding timing violations resulting from process defects in a backfilled metal layer of an integrated circuit | United States of America | Lapsed | 2008-06-24 | 2006-10-03 | 7392496 | 11538187 |
| Trace optimization in flattened netlist by storing and retrieving intermediate results | United States of America | Lapsed | 2010-03-09 | 2007-03-14 | 7676773 | 11724143 |
| Generic Methodology To Support Chip Level Integration Of IP Core Instance Constraints In Integrated Circuits | United States of America | Lapsed | 2010-02-23 | 2007-03-26 | 7669155 | 11728366 |
| Modular cell placement system with fast procedure for finding a levelizing cut point | Modular cell placer Germany (Federal Republic levelizing cut point | Expired | 2007-05-30 | 1997-06-26 | 69737771.7 | 979322997 |
| Method and apparatus for application of proximity correction with unitary segmentation | United States of America | Granted | 2002-12-24 | 1998-03-03 | 6499003 | 09034544 |
| IDDQ test solution for large asics | United States of America | Granted | 2001-04-03 | 1997-11-20 | 6212655 | 08974846 |
| Multiplexer Implementation | United States of America | Lapsed | 2012-04-24 | 2008-08-18 | 8166428 | 12193566 |
| Geometric aerial image simulation | United States of America | Granted | 2001-07-17 | 1999-01-19 | 6263299 | 09234422 |
| Method and apparatus for parallel simultaneous global and detail routing | United States of America | Granted | 2001-11-27 | 1998-04-17 | 6324674 | 09062309 |
| Method and apparatus for parallel routing locking mechanism | United States of America | Granted | 2001-07-31 | 1998-04-17 | 6269469 | 09062418 |
| Physical design automation system and method using hierarchical clusterization and placement improvement based on complete replacement of cell clusters | United States of America | Expired | 1997-08-26 | 1995-03-24 | 5661663 | 08409757 |
| Polydirectional non-orthoginal three layer interconnect architecture | United States of America | Expired | 1998-09-15 | 1995-08-21 | 5808330 | 08517441 |
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| Feature targeted inspection | United States of America | Lapsed | 2005-08-16 | 2004-03-05 | 6931297 | 10794225 |
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| Netlist database | United States of America | Lapsed | 2007-06-12 | 2004-09-30 | 7231623 | 10956862 |
| Method for abstraction of manufacturing test access and control ports to support automated RTL manufacturing test insertion flow for reusable modules | United States of America | Lapsed | 2008-03-04 | 2005-05-27 | 7340700 | 11140392 |
| System and method for providing scalability in an integrated circuit | United States of America | Lapsed | 2006-05-02 | 2004-09-07 | 7038257 | 10936016 |
| Built-in self test technique for programmable impedance drivers for RapidChip and ASIC drivers | United States of America | Lapsed | 2006-05-09 | 2004-05-25 | 7042242 | 10852902 |
| Process and apparatus for placing cells in an IC floorplan | United States of America | Granted | 2007-04-24 | 2004-04-23 | 7210113 | 10830542 |
| Process and apparatus for memory mapping | United States of America | Granted | 2007-05-15 | 2004-04-23 | 7219321 | 10830739 |
| Method of floorplanning and cell placement for integrated circuit chip architecture with internal I/O ring | United States of America | Granted | 2007-02-06 | 2004-09-22 | 7174524 | 10947618 |
| Method for SRAM bitmap verification | United States of America | Lapsed | 2008-12-16 | 2005-10-07 | 7467363 | 11246880 |
| prototype samples | United States of America | Lapsed | 2008-04-22 | 2004-12-09 | 7363608 | 11008854 |
| Accelerating BCB development and debug in advance of platform ACIC | סווונים סומוכן סו אוווכווכם | ru co | 10000 | 04 (0 1004 | 110001 | 10001701 |
| Method and system for outputting a sequence of commands and data described by a flowchart | United States of America | Lapsed | 2008-08-19 | 2004-07-20 | 7415691 | 10894781 |
| Floorplan visualization method using gate count and gate density estimations | United States of America | Granted | 2007-03-27 | 2004-12-15 | 7197735 | 11012741 |
| scan-based testing of integrated circuits | United States of America | Granted | 2007-04-17 | 2005-03-31 | 7206983 | 11097936 |
| Segmented addressable scan architecture and method for implementing | | | | | | |
| Methods for using checksums in X-tolerant test response compaction in scan-based testing of integrated circuits | United States of America | Lapsed | 2008-02-05 | 2005-05-18 | 7328386 | 11131990 |
| System and method for implementing postponed quasi-masking test output compression in integrated circuit | United States of America | Granted | 2007-04-24 | 2004-12-16 | 7210083 | 11013641 |
| Memory generation and placement | United States of America | Granted | 2006-12-26 | 2004-11-17 | 7155688 | 10990589 |
| Delay computation speed up and incrementality | United States of America | Granted | 2007-08-21 | 2005-07-29 | 7260801 | 11192526 |
| Relocatable mixed-signal functions | United States of America | Granted | 2007-12-04 | 2005-05-09 | 7305646 | 11125307 |
| Mixed-signal functions using R-cells | United States of America | Lapsed | 2008-04-15 | 2005-05-24 | 7360178 | 11136180 |
| Scan test expansion module | United States of America | Granted | 2007-07-03 | 2005-04-28 | 7240264 | 11116616 |
| Method and end cell library for avoiding substrate noise in an integrated circuit | United States of America | Lapsed | 2008-08-05 | 2005-12-29 | 7409660 | 11324105 |
| System and Method for Designing Integrated Circuits that Employ Adaptive Voltage and Scaling Optimization | European Patent | Lapsed | | 2008-08-14 | | 087978847 |
| Web-Enabled solutions for Memory compilation to support pre-sales estimation of Memory Size, Performance and Power data for memory components | United States of America | Lapsed | 2010-05-18 | 2005-12-21 | 7720556 | 11315959 |
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| Flexible Architecture Component (FAC) for Efficient Data Integration and Information Interchange using Web Services | United States of America | Lapsed | 2010-06-22 | 2003-07-15 | 7743391 | 10620581 |
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| Method and apparatus for use of hidden decoupling capacitors in an integrated circuit design | United States of America | Granted | 2007-06-12 | 2004-09-28 | 7231625 | 10952194 |
| Sequential Test Pattern Generation Using Clock-Control Design For Testability Structures | United States of America | Lapsed | 2006-03-21 | 2002-03-26 | 7017096 | 10106960 |
| Universal gates for ICs and transformation of netlists for their implementation | United States of America | Lapsed | 2006-01-17 | 2003-08-04 | 6988252 | 10633856 |
| Functionality based package design for integrated circuit blocks | United States of America | Lapsed | 2006-04-04 | 2003-09-29 | 7024637 | 10673721 |
| Incremental dummy metal insertions | United States of America | Granted | 2007-08-21 | 2003-10-10 | 7260803 | 10683369 |
| Comparison of two hierarchical netlist to generate change orders for updating an integrated circuit layout | United States of America | Lapsed | 2006-09-19 | 2003-10-23 | 7111269 | 10693075 |
| Method of partitioning an integrated circuit design for physical design verification | United States of America | Lapsed | 2006-09-12 | 2003-10-29 | 7107559 | 10697357 |
| Efficient Frequency Domain Analysis Of Large Nonlinear Analog Circuits Using Compressed Matrix Storage | United States of America | Expired | 1999-02-02 | 1997-04-02 | 5867416 | 08832487 |
| Apparatus For Defining Properties In Finite-State Machines | United States of America | Expired | 1999-10-12 | 1997-05-09 | 5966516 | 08853578 |
| Low Power Circuits Through Hazard Pulse Suppression | United States of America | Expired | 1999-11-09 | 1997-05-30 | 5983007 | 08866755 |
| Identifying Faulty Programmable Interconnect Resources Of Field Programmable Gate Arrays | United States of America | Granted | 2005-11-15 | 2001-11-26 | 6966020 | 09994299 |
| on chip | United States of America | Lapsed | 2008-08-05 | 2003-11-12 | 7409602 | 10706127 |
| Methodology for debugging RTL simulations of processor based system | | | | | | |
| System and method for mapping logical components to physical locations in an integrated circuit design environment | United States of America | Granted | 2007-09-11 | 2003-12-18 | 7269803 | 10740284 |
| Method and apparatus for testing integrated circuit core modules | United States of America | Lapsed | 2005-05-03 | 2004-01-28 | 6888367 | 10767314 |
| creation | United States of America | Granted | 2007-03-06 | 2004-05-18 | 7188330 | 10847692 |
| Handling of unused coreware with embedded boundary scan chains to avoid the need of a boundary scan synthesis tool during custom instance | | | | | | |
| tool | United States of America | Lapsed | 2008-04-15 | 2004-05-18 | 7360133 | 10847691 |
| Method for creating a JTAG tap controller in a slice for use during custom instance creation to avoid the need of a boundary scan synthesis | | | | | | |
| Method of generating multiple hardware description language configurations for a phase locked loop from a single generic model for integrated circuit design | United States of America | Lapsed | 2006-06-20 | 2004-06-02 | 7065734 | 10859857 |
| Gradient method of mask edge correction | United States of America | Lapsed | 2006-05-02 | 2003-12-18 | 7039896 | 10740359 |
| Method and timing harness for system level static timing analysis | United States of America | Lapsed | 2008-05-13 | 2004-12-06 | 7373626 | 11006349 |
| Method and system for utilizing an isofocal contour to perform optical and process corrections | United States of America | Lapsed | 2006-10-03 | 2004-05-18 | 7117475 | 10848994 |
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| Symbolic simulation driven netlist simplification | United States of America | Lapsed | 2005-01-11 | 2002-03-27 | 6842750 | 10108286 |
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| Pre-silicon verification path coverage | United States of America | Lapsed | 2004-05-11 | 2002-06-10 | 6735747 | 10166797 |
| Process window compliant corrections of design layout | United States of America | Granted | 2007-12-25 | 2002-12-27 | 7313508 | 10330929 |
| Architecture and/or method for using input/output affinity region for flexible use of hard macro I/O buffers | United States of America | Lapsed | 2006-05-09 | 2002-09-11 | 7043703 | 10241317 |
| Interactive representation of structural dependencies in semiconductor design flows | United States of America | Lapsed | 2005-02-15 | 2002-07-31 | 6857108 | 10210651 |
| Design methodology for dummy lines | United States of America | Granted | 2005-11-01 | 2002-11-06 | 6961915 | 10290019 |
| integrated circuit | United States of America | Granted | 2006-06-27 | 2002-12-13 | 7069523 | 10318623 |
| Automated selection and placement of memory during design of an | | | | | | |
| Diagnostic architecture using FPGA core in system on a chip design | United States of America | Lapsed | 2004-12-07 | 2000-10-06 | 6829751 | 09684868 |
| Virtual path for interconnect fabric using bandwidth process | United States of America | Lapsed | 2008-01-22 | 2002-10-31 | 7322021 | 10285301 |
| Floor plan-based power bus analysis and design tool for integrated circuits | United States of America | Granted | 2004-01-06 | 1999-03-16 | 6675139 | 09268867 |
| Method for estimating porosity of hardmacs | United States of America | Granted | 2003-03-11 | 2001-03-14 | 6532572 | 09808510 |
| Method for reducing reticle set cost | United States of America | Lapsed | 2006-10-24 | 2003-04-17 | 7127698 | 10417706 |
| Process for layout of memory matrices in integrated circuits | United States of America | Granted | 2004-10-12 | 2002-09-25 | 6804811 | 10254616 |
| Split and merge design flow concept for fast turnaround time of circuit layout design | United States of America | Granted | 2005-05-24 | 2003-01-09 | 6898770 | 10339821 |
| Floor plan development electromigration and voltage drop analysis tool | United States of America | Lapsed | 2006-03-21 | 1999-03-16 | 7016794 | 09268902 |
| Macro cell for integrated circuit physical layer interface | United States of America | Granted | 2007-04-03 | 2004-03-26 | 7200832 | 10810294 |
| Recording and Displaying Logic Circuit Simulation Waveforms | United States of America | Granted | 2011-03-01 | 2003-06-02 | 7899659 | 10452260 |
| Method Of Making A Semiconductor Device By Balancing Shallow Trench Isolation Stress and Optical Proximity Effects | Taiwan | Lapsed | 2012-09-11 | 2005-11-14 | 1372347 | 094139974 |
| Datapath bitslice technology | United States of America | Granted | 2004-04-27 | 2003-04-29 | 6728936 | 10425155 |
| Optimized bond out method for flip chip wafers | United States of America | Lapsed | 2006-06-20 | 2004-01-14 | 7065721 | 10757752 |
| Intelligent engine for protection against injected crosstalk delay | United States of America | Lapsed | 2005-09-20 | 2003-06-02 | 6948142 | 10453819 |
| Methodology for generating a modified view of a circuit layout | United States of America | Lapsed | 2006-07-11 | 2003-08-26 | 7076759 | 10649215 |
| Method of parasitic extraction from a previously calculated capacitance solution | United States of America | Granted | 2007-02-27 | 2004-12-17 | 7185298 | 11015114 |
| Method of generating a schematic driven layout for a hierarchical integrated circuit design | United States of America | Lapsed | 2006-07-25 | 2003-11-10 | 7082589 | 10704922 |
| Deriving Statistical Device Models From Worst-Case Files | United States of America | Granted | 2002-03-12 | 1999-04-12 | 6356861 | 09291157 |
| Methods and systems for automatic verification of specification document to hardware design | United States of America | Lapsed | 2006-08-22 | 2003-07-22 | 7096440 | 10624347 |
| Method Of Making A Semiconductor Device By Balancing Shallow Trench Isolation Stress and Optical Proximity Effects | United States of America | Granted | 2007-02-06 | 2004-11-18 | 7174532 | 10992031 |
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| Wethod of determining delay in logic cell models | United States of America | Granted | 2000-02-22 | 1998-03-31 | 6028995 | 09052914 |
|---|--------------------------|---------|------------|------------|----------|----------|
| generation | United States of America | Granted | 2001-10-23 | 1998-12-08 | 6308292 | 09207191 |
| File driven mask insertion for automatic test equipment test pattern | United States of America | Lapsed | 2004-07-20 | 2001-04-05 | 6/66499 | 09828553 |
| Systematic skew reduction through buffer resizing | United States of America | Granted | 2002-07-23 | 2000-01-31 | 6425114 | 09494605 |
| Insertion | United States of America | Granted | 2003-02-11 | 2000-10-10 | 6519746 | 09685990 |
| Method and apparatus for minimization of net delay by optimal buffer | |) - | | | | |
| Method and apparatus for formula area and delay minimization | United States of America | Granted | 2003-07-01 | 2000-10-01 | 6587990 | 09678201 |
| Integrated circuit having on-chip capacitors for supplying power to portions of the circuit requiring high-transient peak power | United States of America | Granted | 2003-04-08 | 2000-03-10 | 6546538 | 09523224 |
| Method and apparatus for optimal critical netlist area selection | United States of America | Granted | 2003-03-11 | 2000-10-02 | 6532582 | 09678481 |
| System and method for efficient layout of functionally extraneous cells | United States of America | Granted | 2002-10-22 | 2000-05-18 | 6470484 | 09573806 |
| Method of control cell placement to minimize connection length and cell delay | United States of America | Granted | 2003-08-19 | 2001-06-15 | 6609238 | 09882114 |
| Method of global placement of control cells and hardmac pins in a datapath macro for an integrated circuit design | United States of America | Granted | 2003-01-14 | 2001-06-19 | 6507937 | 09885596 |
| Balanced clock placement for integrated circuits containing megacells | United States of America | Granted | 2002-11-12 | 2001-02-15 | 6480994 | 09788257 |
| Static timing analysis validation tool for ASIC cores | United States of America | Granted | 2003-07-22 | 2001-04-16 | 6598213 | 09836129 |
| Interscalable interconnect | United States of America | Granted | 2003-11-25 | 2001-10-30 | 6654946 | 10021414 |
| Enhanced fault coverage | United States of America | Lapsed | 2004-06-01 | 2001-11-30 | 6745358 | 09997757 |
| Integrated circuit design incorporating a power mesh | United States of America | Granted | 2002-11-12 | 1998-06-29 | 6480989 | 09106890 |
| Method for minimizing clock skew for an integrated circuit | United States of America | Granted | 2003-07-15 | 2001-03-06 | 6594807 | 09800532 |
| Direct transformation of engineering change orders to synthesized IC chip designs | United States of America | Granted | 2003-11-18 | 2001-11-13 | 6651239 | 10008089 |
| Changing clock delays in an integrated circuit for skew optimization | United States of America | Granted | 2003-04-15 | 2001-11-20 | 6550045 | 09991574 |
| Designing memory for testability to support scan capability in an asic design | United States of America | Granted | 2002-01-22 | 2000-12-11 | 6341092 | 09735233 |
| System and method for identifying and eliminating bottlenecks in integrated circuit designs | United States of America | Lapsed | 2004-06-29 | 2002-02-27 | 6757877 | 10083411 |
| Method and system for checking for power errors in ASIC designs | United States of America | Lapsed | 2004-12-07 | 2002-06-04 | 6829754 | 10163208 |
| Optical proximity correction driven hierarchy | United States of America | Lapsed | 2004-11-02 | 2002-03-14 | 6813758 | 10097419 |
| Overlap remover manager | United States of America | Lapsed | 2004-03-02 | 2002-02-07 | 6701503 | 10072008 |
| Integrated circuit design flow with capacitive margin | United States of America | Lapsed | 2004-10-26 | 2002-07-10 | 6810505 | 10192989 |
| Ratio testing | United States of America | Granted | 2003-03-11 | 2002-07-12 | 6532431 | 10194134 |
| Process for designing comparators and adders of small depth | United States of America | Lapsed | 2006-03-28 | 2003-06-24 | 7020865 | 10602570 |
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| Semiconductor cell having a variable transistor width | United States of America | Expired | 1997-04-08 | 1995-05-04 | 5619420 | 08434660 |
|---|--------------------------|---------|------------|------------|----------|----------|
| Method for reducing simulation overhead for external models | United States of America | Granted | 2003-06-17 | 2001-06-15 | 6581194 | 09882899 |
| IC timing analysis with known false paths | United States of America | Granted | 2002-10-08 | 2001-05-31 | 6463572 | 09871129 |
| Advanced modular cell placement system with minimizing maximal cut driven affinity system | United States of America | Expired | 1998-11-10 | 1996-06-28 | 5835381 | 08672333 |
| Advanced modular cell placement system with optimization of cell neighborhood system | United States of America | Expired | 1999-10-26 | 1996-06-28 | 5971588 | 08672423 |
| Memory having direct strap connection to power supply | United States of America | Expired | 1998-09-15 | 1996-04-30 | 5808900 | 08641444 |
| Intermediate test file conversion and comparison | United States of America | Expired | 1999-10-26 | 1996-12-23 | 5974248 | 08772400 |
| Method for low velocity measurement of fluid flow | United States of America | Expired | 1999-03-09 | 1996-10-15 | 5880377 | 08735450 |
| Method for detecting bus shorts in semiconductor devices | United States of America | Expired | 1999-04-27 | 1996-12-23 | 5898705 | 08771004 |
| Efficient multiprocessing for cell placement of integrated circuits | United States of America | Expired | 1999-01-12 | 1997-02-11 | 5859782 | 08798648 |
| Parallel processor implementation of net routing | United States of America | Expired | 1999-07-27 | 1997-02-11 | 5930500 | 08798880 |
| time of embedded cores and other integrated circuits | United States of America | Expired | 1998-10-13 | 1997-05-27 | 5822228 | 08863798 |
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| Wethod and apparation for parallel (%) income to provide a line apparation for parallel (%) income to provide a line apparation for parallel (%) income to provide a line apparation for parallel (%) income to provide a line apparation for parallel (%). | United States of America | Expired | 2000-05-02 | 1997-08-06 | 6058254 | 08906948 |
| Wetnod and apparatus for determining wire routing | United States of America | Expired | 2001-02-13 | 1997-08-06 | 61866/6 | 08906947 |
| Method and apparatus for congestion removal | United States of America | Expired | 2000-05-30 | 1997-08-06 | 6068662 | 08906945 |
| High density gate array base cell architecture | United States of America | Expired | 1997-12-16 | 1996-03-08 | 5698873 | 08613040 |
| Determining Timing of Integrated Circuits | United States of America | Lapsed | 2009-09-29 | 1999-06-24 | 7596483 | 09344169 |
| Method of selecting and synthesizing metal interconnect wires in integrated circuits | United States of America | Granted | 2001-02-13 | 1998-01-14 | 6189131 | 09007242 |
| Modifying timing graph to avoid given set of paths | United States of America | Granted | 2001-09-18 | 1997-11-05 | 6292924 | 08964997 |
| Placement and routing of circuits using a combined processing/buffer cell | United States of America | Granted | 2004-03-30 | 1998-07-10 | 6714903 | 09113995 |
| Method for optimizing routing mesh segment width | United States of America | Granted | 2001-03-13 | 1998-02-03 | 6202196 | 09017378 |
| Estimation of voltage drop and current densities in ASIC power supply mesh | United States of America | Granted | 2000-02-22 | 1998-03-20 | 6028440 | 09045190 |
| 4K derating scheme for propagation delay and setup/hold time computation | United States of America | Granted | 2002-11-19 | 2000-02-29 | 6484297 | 09515250 |
| High density gate array cell architecture with sharing of well taps between cells | United States of America | Expired | 1999-11-02 | 1997-03-28 | 5977574 | 08829520 |
| Method and apparatus for analyzing digital circuits | United States of America | Expired | 1999-05-11 | 1997-09-30 | 5903577 | 08940912 |
| Method for generating format-independent electronic circuit representations | United States of America | Expired | 1999-11-30 | 1997-05-23 | 5995730 | 08862233 |
| Spice to verilog netlist translator and design methods using spice to verilog and verilog to spice translation | United States of America | Lapsed | 2004-09-14 | 2001-10-05 | 6792579 | 09972100 |
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| 08477490 | 5703788 | 1995-06-07 | 1997-12-30 | Expired | United States of America | Configuration management and automated test system ASIC design software |
| 08683287 | 5812416 | 1996-07-18 | 1998-09-22 | Expired | United States of America | Integrated circuit design decomposition |
| | | | | | | Microelectronic integrated circuit including hexagonal CMOS NAND gate |
| 08396541 | 6005264 | 1995-03-01 | 1999-12-21 | Expired | United States of America | device |
| 08377844 | 5644498 | 1995-01-25 | 1997-07-01 | Expired | United States of America | Timing shell generation through netlist reduction |
| 08367556 | 5665989 | 1995-01-03 | 1997-09-09 | Expired | United States of America | Programmable microsystems in silicon |
| | | | | | | High density gate array cell architecture with metallization routing tracks |
| 08580908 | 5990502 | 1995-12-29 | 1999-11-23 | Expired | United States of America | having a variable pitch |
| | | | | | | Optimization processing for integrated circuit physical design |
| | | | | | | automation system using optimally switched fitness improvement |
| 08229616 | 6493658 | 1994-04-19 | 2002-12-10 | Granted | United States of America | algorithms |
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| 08229949 | 5682322 | 1994-04-19 | 1997-10-28 | Expired | United States of America | automation system using chaotic fitness improvement method |
| 08306189 | 5638293 | 1994-09-13 | 1997-06-10 | Expired | United States of America | Optimal pad location method for microelectronic circuit cell placement |
| | | | | | | Automated generation of megacells in an integrated circuit design |
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| 09879841 | 6868535 | 2001-06-12 | 2005-03-15 | Lapsed | United States of America | Method and apparatus for optimizing the timing of integrated circuits |
| 09842350 | 6470487 | 2001-04-25 | 2002-10-22 | Granted | United States of America | Parallelization of resynthesis |
| 09841825 | 6553551 | 2001-04-25 | 2003-04-22 | Granted | United States of America | Timing recomputation |
| | | | | | | Process for solving assignment problems in integrated circuit designs |
| 09833142 | 6453453 | 2001-04-11 | 2002-09-17 | Granted | United States of America | with unimodal object penalty functions and linearly ordered set of boxes |
| | | | | | | Congestion based cost factor computing apparatus for integrated circuit |
| 09804939 | 9202336 | 2001-03-13 | 2003-01-07 | Lansed | United States of America | Channel router with buffer insertion |
| 09849691 | 7076406 | 2001-05-04 | 2006-07-11 | Lapsed | United States of America | Minimal bends connection models for wire density calculation |
| 13058176 | 8539424 | 2011-02-08 | 2013-09-17 | Lapsed | United States of America | SYSTEM AND METHOD FOR DESIGNING INTERGRATED CIRCUITS THAT EMPLOY ADAPTIVE VOLTAGE SCALING OPTIMIZATION |
| 3555 | 100000 | 30 3001 | 1000 00 15 | | 1 1 2 2 2 2 2 2 2 2 2 2 2 2 2 2 2 2 2 2 | Advanced modular cell placement system with cell placement |
| 000/2233 | 2000022 | 1990-00-20 | T330-03-T3 | Expired | Office of States of Afficiated | Advanced modular cell placement system with dispersion-driven because of |
| 08672652 | 5870312 | 1996-06-28 | 1999-02-09 | Expired | United States of America | levelizing system |
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| | | | | | | |

| Generic gate level model for characterization of glitch power in logic cells | United States of America | Expired | 1997-11-25 | 1996-06-10 | 5691910 | 08661186 |
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| Test shells for protecting proprietary information in asic cores | United States of America | Expired | 1999-05-11 | 1996-03-08 | 5903578 | 08611325 |
| Protecting proprietary asic design information using boundary scan on selective inputs and outputs | United States of America | Expired | 1997-06-10 | 1996-03-14 | 5638380 | 08616070 |
| Gate netlist to register transfer level conversion tool | United States of America | Expired | 1999-02-02 | 1996-06-19 | 5867395 | 08668064 |
| Verification of an Extracted Timing Model File | United States of America | Lapsed | 2009-08-18 | 2006-03-15 | 7577928 | 11376781 |
| Modeling and estimating crosstalk noise and detecting false logic | United States of America | Expired | 1996-10-22 | 1994-06-29 | 5568395 | 08268920 |
| Chip core size estimation | United States of America | Granted | 2003-02-25 | 2001-04-18 | 6526553 | 09837492 |
| Method of cell placement for an itegrated circuit chip comprising integrated placement and cell overlap removal | United States of America | Expired | 1997-04-08 | 1994-09-13 | 5619419 | 08306182 |
| Fail-safe distributive processing method for producing a highest fitness cell placement for an integrated circuit chip | United States of America | Expired | 1998-09-29 | 1994-04-19 | 5815403 | 08229954 |
| Physical design automation system and process for designing integrated circuit chips using multiway partitioning with constraints | United States of America | Expired | 1997-12-16 | 1995-09-08 | 5699265 | 08525839 |
| Gridless router using maze and line probe techniques | United States of America | Granted | 2003-04-08 | 2001-03-08 | 6545288 | 09802043 |
| Triangular semiconductor NAND gate | United States of America | Expired | 1999-01-26 | 1995-08-21 | 5864165 | 08517451 |
| Optical corrective techniques with reticle formation and reticle stitching to provide design flexibility | United States of America | Expired | 1997-09-02 | 1995-06-07 | 5663017 | 08477827 |
| Physical design automation system and process for designing integrated circuit chips using fuzzy cell clusterization | United States of America | Expired | 1998-01-27 | 1995-11-20 | 5712793 | 08560588 |
| Computer implemented method for leveling interconnect wiring density in a cell placement for an integrated circuit chip | United States of America | Expired | 1998-11-10 | 1995-11-20 | 5835378 | 08560834 |
| Distribution dependent clustering in buffer insertion of high fanout nets | United States of America | Granted | 2002-11-26 | 2001-03-28 | 6487697 | 09820059 |
| Method and apparatus for testing of semiconductor devices | United States of America | Expired | 1997-09-16 | 1995-10-20 | 5668745 | 08545879 |
| Loop-back test system and method | United States of America | Expired | 1998-07-28 | 1996-01-17 | 5787114 | 08586174 |
| Mask correction for photolithographic processes | United States of America | Lapsed | 2005-08-23 | 2001-06-12 | 6934410 | 09879664 |
| Method for metal delay testing in semiconductor devices | United States of America | Expired | 1998-08-18 | 1996-02-29 | 5796265 | 08608609 |
| Advanced modular cell placement system with iterative one dimensional preplacement optimization | United States of America | Expired | 1999-04-06 | 1996-06-28 | 5892688 | 08672335 |
| Advanced modular cell placement system with density driven capacity penalty system | United States of America | Expired | 1999-02-02 | 1996-06-28 | 5867398 | 08672534 |
| Advanced modular cell placement system with wire length driven affinity system | United States of America | Expired | 1998-11-03 | 1996-06-28 | 5831863 | 08672725 |
| Advanced modular cell placement system with functional sieve optimization technique | United States of America | Expired | 1999-10-05 | 1996-06-28 | 5963455 | 08672936 |
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| Method and device for fast and accurate parasitic extraction | United States of America | Expired | 2001-01-30 | 1997-08-06 | 6182269 | 08907183 |
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| Method and computer program for detailed routing of an integrated circuit design with multiple routing rules and net constraints | United States of America | Lapsed | 2008-05-06 | 2005-10-05 | 7370309 | 11244486 |
| System and Method for Designing Integrated Circuits that Employ Adaptive Voltage and Scaling Optimization | Japan | Abandoned | | 2008-08-14 | | 2011522952 |
| Method and apparatus for coarse global routing | United States of America | Granted | 2001-07-10 | 1998-04-17 | 6260183 | 09062246 |
| Generation in Multi-Corner STA Sign-Off Flow | United States of America | Lapsed | 2013-09-17 | 2008-02-26 | 8539411 | 12072478 |
| Method of calculating macrocell power and delay values | United States of America | Expired | 1998-06-16 | 1995-05-15 | 5768130 | 08441539 |
| On-the-fly RTL instructor for advanced DFT and design closure | United States of America | Lapsed | 2008-10-21 | 2005-10-11 | 7441210 | 11247630 |
| physical design automation system | United States of America | Granted | 2000-12-05 | 1994-04-19 | 6155725 | 08230383 |
| Cell placement representation and transposition for integrated circuit | | | | | | |
| Method and computer program for spreading trace segments in an integrated circuit package design | United States of America | Lapsed | 2008-01-29 | 2005-11-09 | 7325216 | 11271991 |
| Physical Layout Versus Schematic Design Comparison | United States of America | Lapsed | 2009-01-20 | 2005-12-29 | 7480878 | 11321260 |
| Method in integrating clock tree synthesis and timing optimization for an integrated circuit design | United States of America | Granted | 2003-04-15 | 2001-06-19 | 6550044 | 09885589 |
| Assignment of cell coordinates | United States of America | Granted | 2003-10-21 | 2001-04-25 | 6637016 | 09841824 |
| Integrated Circuit With Relocatable Processor Hardmac | China | Lapsed | 2010-05-12 | 2006-04-06 | ZL 200610084168.0 | 2006100841680 |
| Optimization of Flipflop Initialization Structures with Respect to Design Size and Design Closure Effort from RTL to Netlist | United States of America | Lapsed | 2009-06-09 | 2006-12-06 | 7546560 | 11634683 |
| Method and apparatus for local optimization of the global routing | United States of America | Granted | 2001-09-11 | 1998-04-17 | 6289495 | 09062205 |
| Mask correction optimization | United States of America | Granted | 2003-08-26 | 2001-06-12 | 6611953 | 09879846 |
| Efficient Cell Swapping Algorithm for Leakage Power Reduction in A Multi-Threshold Voltage Process | United States of America | Granted | 2010-12-07 | 2007-06-20 | 7849422 | 11765691 |
| Defect isolation using scan-path testing and electron beam probing in multi-level high density asics | United States of America | Expired | 1997-09-02 | 1995-10-19 | 5663967 | 08545462 |
| System simulation for testing integrated circuit models | United States of America | Expired | 1999-05-11 | 1996-07-18 | 5903475 | 08683396 |
| Method for local rip-up and reroute of signal paths in an IC design | United States of America | Expired | 1998-10-20 | 1995-06-16 | 5825659 | 08491433 |
| Physical design automation system and process for designing integrated circuit chips using highly parallel sieve optimization with multiple jiggles | United States of America | Expired | 1999-06-01 | 1995-11-20 | 5909376 | 08560848 |
| RTL analysis tool | United States of America | Granted | 2001-09-18 | 1998-02-20 | 6292931 | 09027520 |
| Advanced modular cell placement system with fast procedure for finding a levelizing cut point | United States of America | Expired | 1999-02-09 | 1996-06-28 | 5870311 | 08671699 |
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| Method for estimating a frequency-based ramptime limit | United States of America | Granted | 2007-04-17 | 2005-01-14 | 7207021 | 11036822 |
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| chip PLL | United States of America | Granted | 2007-04-10 | 2005-02-18 | 7202656 | 11061292 |
| Methods and structure for improved high-speed TDF testing using on- | | | | | | |
| RRAM memory timing learning tool | United States of America | Granted | 2007-04-03 | 2004-11-30 | 7200826 | 11000104 |
| Multimode Delay Analysis for Simplifying Integrated Circuit Design Timing Models | United States of America | Lapsed | 2009-03-31 | 2005-08-17 | 7512918 | 11205365 |
| custom functions | United States of America | Granted | 2009-01-13 | 2005-05-20 | 7478354 | 11133815 |
| Use of configurable mixed-signal building block functions to accomplish | | | | | | |
| Method for tracing paths within a circuit | United States of America | Granted | 2007-11-20 | 2005-03-07 | 7299431 | 11074173 |
| Yield-limiting design-rules-compliant pattern library generation and layout inspection | United States of America | Lapsed | 2008-11-25 | 2005-12-30 | 7458060 | 11323468 |
| Application specific configurable logic IP | United States of America | Lapsed | 2008-11-11 | 2005-07-07 | 7451426 | 11176514 |
| Integrated circuit with relocatable processor hardmac | United States of America | Granted | 2007-12-25 | 2005-04-06 | 7313775 | 11099772 |
| Synthesis shell generation and use in ASIC design | United States of America | Granted | 2002-02-05 | 1995-03-23 | 6345378 | 08409191 |
| Method and Computer Program for Static Timing Analysis with Delay De- Rating and Clock Conservatism Reduction | United States of America | Lapsed | 2009-01-20 | 2006-08-18 | 7480881 | 11465662 |
| Method of generating an optimal clock buffer set for minimizing clock skew in balanced clock trees | United States of America | Granted | 2002-08-27 | 2001-06-06 | 6442737 | 09876736 |
| Efficient top-down characterization method | United States of America | Granted | 2002-07-16 | 1998-02-20 | 6421818 | 09027438 |
| Resource estimation for design planning | United States of America | Lapsed | 2008-12-09 | 2005-08-01 | 7464345 | 11194299 |
| System and Method for Designing Integrated Circuits that Employ Adaptive Voltage and Scaling Optimization | Taiwan | Lapsed | 2013-08-21 | 2009-11-06 | 1406147 | 098137820 |
| RTL analysis for improved logic synthesis | United States of America | Granted | 2001-09-25 | 1998-02-20 | 6295636 | 09027283 |
| Method of handling macro components in circuit design synthesis | United States of America | Granted | 2002-04-23 | 1998-02-20 | 6378123 | 09027429 |
| Method and system for converting netlist of integrated circuit between libraries | United States of America | Lapsed | 2008-05-27 | 2005-10-24 | 7380223 | 11257206 |
| Method and apparatus for controlling congestion during integrated circuit design resynthesis | United States of America | Lapsed | 2008-07-15 | 2005-10-26 | 7401313 | 11258738 |
| Cell Library Management for Power Optimization | United States of America | Lapsed | 2009-02-24 | 2007-04-02 | 7496867 | 11732092 |
| Automatic generation of timing constraints for the validation/signoit of test structures | United States of America | Lapsed | 2009-02-10 | 2006-06-29 | 7490307 | 11478044 |
| IP placement validation | United States of America | Lapsed | 2008-12-23 | 2005-08-16 | 7469398 | 11204670 |
| Germany (Federal Republid Optical Proximity Correction Method And Apparatus | Germany (Federal Republi | Granted | 2005-07-06 | 1998-04-08 | 69830782.8 | 981064298 |
| Method and apparatus for indentifying causes of poor silicon-to-simulation correlation | United States of America | Granted | 2002-12-10 | 2001-05-03 | 6493851 | 09848489 |
| Method and System for Classifying an Integrated Circuit for Optical Proximity Correction | Method and System Germany (Federal Republic Proximity Correction | Granted | 2010-09-22 | 2003-11-14 | 60334275.2 | 030262091 |
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| Memory timing model with back-annotating | United States of America | Lapsed | 2008-08-19 | 2005-12-19 | 7415686 | 11311388 |
| RRAM Memory Error Emulation | United States of America | Lapsed | 2009-02-17 | 2005-10-24 | 7493519 | 11257470 |
| creation | United States of America | Lapsed | 2006-04-25 | 2003-10-27 | 7036102 | 10694208 |
| Method and system for mapping netlist of integrated circuit to design | United States of America | Lapsed | 2008-07-22 | 2005-10-24 | 7404166 | 11257289 |
| Generic method and apparatus for implementing source synchronous interface in platform ASIC | United States of America | Granted | 2007-02-27 | 2004-04-06 | 7185301 | 10819254 |
| Modular collection of spare gates for use in hierarchical integrated circuit design process | United States of America | Lapsed | 2003-11-18 | 2001-06-20 | 6650139 | 09885896 |
| Method and computer program for estimating speed-up and slow-down net delays for an integrated circuit design | United States of America | Granted | 2007-02-13 | 2005-06-24 | 7178121 | 11165778 |
| OPC based illumination optimization with mask error constraints | United States of America | Granted | 2007-09-04 | 2004-03-05 | 7264906 | 10794683 |
| System And Method For Implementing Multiple Instantiated Configurable Peripherals In A Circuit Design | United States of America | Lapsed | 2009-11-17 | 2004-04-01 | 7620743 | 10817419 |
| METHOD AND APPARATUS OF CORE TIMING PREDICTION OF CORE LOGIC IN THE CHIP-LEVEL IMPLEMENTATION PROCESS THROUGH AN OVER-CORE WINDOW ON A CHIP-LEVEL ROUTING LAYER | United States of America | Lapsed | 2010-06-15 | 2006-04-28 | 7739639 | 11413236 |
| Method of optimizing critical path delay in an integrated circuit design | United States of America | Granted | 2007-02-20 | 2004-10-27 | 7181712 | 10975981 |
| Test structures in unused areas of semiconductor integrated circuits and methods for designing the same | United States of America | Granted | 2007-05-29 | 2004-06-04 | 7223616 | 10862049 |
| Method for performing design rule check of integrated circuit | United States of America | Lapsed | 2008-07-29 | 2005-10-05 | 7406671 | 11243839 |
| Enabling efficient design reuse in platform ASICs | United States of America | Granted | 2007-11-20 | 2005-08-16 | 7299446 | 11204669 |
| Method of early physical design validation and identification of texted metal short circuits in an integrated circuit design | United States of America | Granted | 2006-12-12 | 2004-09-22 | 7149989 | 10947498 |
| Method of associating timing violations with critical structures in an integrated circuit design | United States of America | Lapsed | 2008-05-27 | 2004-11-08 | 7380228 | 10984115 |
| Timing abstraction and partitioning strategy | United States of America | Granted | 2006-10-24 | 2002-06-27 | 7127692 | 10186263 |
| Method and apparatus for detecting nets physically changed and electrically affected by design ECO | United States of America | Granted | 2007-01-23 | 2004-08-10 | 7168055 | 10914921 |
| Method and Apparatus for Detecting Defects in Integrated Circuit Die from Simulation of Statistical Outlier Signatures | United States of America | Lapsed | 2009-11-10 | 2005-12-29 | 7617427 | 11324084 |
| Special tie-high/low cells for single metal layer route changes | United States of America | Granted | 2007-03-13 | 2004-08-30 | 7191424 | 10929218 |
| Compact custom layout for RRAM column controller | United States of America | Granted | 2007-03-20 | 2004-09-08 | 7194717 | 10936202 |
| Method and computer program for incremental placement and routing with nested shells | United States of America | Lapsed | 2008-08-19 | 2005-10-05 | 7415687 | 11244530 |
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| Debugging Simulation Of A Circuit Core Using Pattern Recorder, Player & Samp; Checker | United States of America | Granted | 2011-07-12 | 2004-10-23 | 7979833 | 10971911 |
| Cell builder for different layer stacks | United States of America | Granted | 2008-02-19 | 2004-12-13 | 7334206 | 11010745 |
| Yield driven memory placement system | United States of America | Granted | 2007-01-23 | 2004-06-23 | 7168052 | 10875128 |
| Method and systems for utilizing simplified resist process models to perform optical and process corrections | United States of America | Lapsed | 2009-02-24 | 2005-02-11 | 7494752 | 11056838 |
| Automatic generation of correct minimal clocking constraints for a semiconductor product | United States of America | Lapsed | 2008-05-27 | 2005-06-13 | 7380229 | 11151043 |
| Integrated circuit having integrated programmable gate array and method of operating the same | United States of America | Lapsed | 2005-08-23 | 2002-03-26 | 6934597 | 10106432 |
| Method and system of generic implementation of sharing test pins with I/O cells | United States of America | Granted | 2007-02-20 | 2004-11-12 | 7181359 | 10988081 |
| recovery and flexible macro placement, base platform for ICs, and process of creating ICs | United States of America | Granted | 2007-05-08 | 2004-10-29 | 7216323 | 10976518 |
| Process for designing hase platforms for IC design to permit resource | United States of America | Lapsed | 71-70-8007 | 2005-03-03 | /331031 | 110/1623 |
| Automatic Recognition of Geometric Points in a larget IC Design for OPC Mask Quality Calculation | United States of America | Lapsed | 2009-02-17 | 2004-12-01 | 7493577 | 11002576 |
| System for performing automatic test pin assignment for a programmable device | United States of America | Lapsed | 2007-10-30 | 2004-12-17 | 7290194 | 11016192 |
| Interconnect integrity verification | United States of America | Lapsed | 2008-09-09 | 2004-12-07 | 7424690 | 11005690 |
| Method for Generalizing Design Attributes in a Design Capture Environment | United States of America | Lapsed | 2009-02-24 | 2005-11-30 | 7496861 | 11290186 |
| Method and BIST architecture for fast memory testing in platform-based integrated circuit | United States of America | Granted | 2007-05-08 | 2004-11-30 | 7216278 | 10999493 |
| Frequency dependent timing margin | United States of America | Granted | 2007-11-20 | 2005-01-18 | 7299435 | 11037306 |
| Memory tiling architecture | United States of America | Granted | 2007-04-17 | 2004-11-16 | 7207026 | 10990237 |
| Method of buffer insertion to achieve pin specific delays | United States of America | Granted | 2007-07-10 | 2005-01-24 | 7243324 | 11041489 |
| Method of interconnect for multi-slot metal-mask programmable relocatable function placed in an I/O region | United States of America | Lapsed | 2007-11-06 | 2005-05-02 | 7292063 | 11120067 |
| System for avoiding false path pessimism in estimating net delay for an integrated circuit design | United States of America | Lapsed | 2008-02-19 | 2005-12-29 | 7334204 | 11324082 |
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| RRAM backend flow | United States of America | Lapsed | 2006-04-11 | 2005-02-09 | 7028274 | 11054460 |
| Cell-based method for creating slotted metal in semiconductor designs | United States of America | Granted | 2008-02-05 | 2003-12-09 | 7328417 | 10732395 |
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| Accurate density calculation with density views in layout databases | United States of America | Granted | 2007-02-06 | 7004-07-30 | 717/576 | 10003836 |
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| Method of implementing an engineering change order in an integrated circuit design by windows | United States of America | Granted | 2007-06-12 | 2004-12-17 | 7231626 | 11015123 |
| Multiple buffer insertion in global routing | United States of America | Granted | 2007-08-14 | 2004-11-19 | 7257791 | 10992999 |
| Process and apparatus to assign coordinates to nodes of logical trees without increase of wire lengths | United States of America | Lapsed | 2006-09-19 | 2004-08-27 | 7111267 | 10928799 |
| OPC edge correction based on a smoothed mask design | United States of America | Granted | 2007-08-21 | 2004-12-14 | 7260814 | 11012618 |
| Method of estimating a total path delay in an integrated circuit design with stochastically weighted conservatism | United States of America | Granted | 2007-05-01 | 2004-11-19 | 7213223 | 10994114 |
| Method of identifying floorplan problems in an integrated circuit layout | United States of America | Granted | 2007-08-28 | 2005-03-15 | 7263678 | 11079998 |
| Flexible Design of Memory use in Integrated Circuits | European Patent | Application | | 2004-09-08 | | 040213241 |
| Method and system for improving aerial image simulation speeds | United States of America | Lapsed | 2008-07-29 | 2005-12-16 | 7406675 | 11305542 |
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| Negative bias temperature instability modeling | United States of America | Granted | 2007-06-05 | 2005-02-18 | 7228516 | 11061581 |
| R-cells containing CDM clamps | United States of America | Granted | 2007-09-18 | 2005-05-11 | 7272802 | 11126880 |
| Gate-level netlist reduction for simulating target modules of a design | United States of America | Lapsed | 2009-10-20 | 2004-04-26 | 7606692 | 10832226 |
| fault truncated scan test pattern for an integrated circuit design | United States of America | Lapsed | 2006-06-06 | 2003-12-03 | 7058909 | 10728036 |
| Method of generating an efficient stuck-at fault and transition delay | | | | | | |
| Device for estimating cell delay from a table with added voltage swing | United States of America | Granted | 2007-02-20 | 2004-06-28 | 7181710 | 10879768 |
| Method For Delay-Fault Testing In Field Programmable Gate Arrays | United States of America | Granted | 2008-08-12 | 2005-03-24 | 7412343 | 10516583 |
| Reduced voltage quiescent current test methodology for integrated circuits | United States of America | Granted | 2001-05-29 | 1998-02-11 | 6239609 | 09022353 |
| PLACEMENT OF A FLOOR-PLAN REGION | United States of America | Lapsed | 2010-04-20 | 2006-05-22 | 7703059 | 11438644 |
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| Four point measurement technique for programmable impedance drivers RapidChip and ASIC devices | United States of America | Granted | 2006-12-19 | 2004-09-28 | 7152012 | 10952213 |
| Engineering change order scenario manager | United States of America | Lapsed | 2008-02-12 | 2004-07-30 | 7331028 | 10902987 |
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| Fault ¹ Adjust | United States of America | Granted | 2005-03-29 | 2002-08-27 | 6874108 | 10228444 |
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| Automatic Recognition of an Optically Periodic Structure in an Integrated Circuit Design | Japan | Lapsed | 2012-11-30 | 2003-08-21 | 5143994 | 2003297248 |
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| Methods And Apparatus For Making Placement Sensitive Logic Modifications | United States of America | Lapsed | 2009-10-27 | 2006-10-18 | 7610568 | 11550448 |
| Method to selectively identify at risk die based on location within the reticle | United States of America | Granted | 2007-12-04 | 2004-11-23 | 7305634 | 10996074 |
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| Process and apparatus for fast assignment of objects to a rectangle | United States of America | Lapsed | 2006-09-19 | 2003-10-17 | 7111264 | 10688460 |
| Method and apparatus for general systematic application of proximity correction | United States of America | Granted | 2001-01-16 | 1998-03-03 | 6175953 | 09034658 |
| Platform ASIC reliability | United States of America | Granted | 2007-08-07 | 2005-11-28 | 7254761 | 11287927 |
| Method and apparatus for performing logical transformations for global routing | United States of America | Lapsed | 2008-07-08 | 2004-03-17 | 7398486 | 10803516 |
| Process and apparatus for characterizing intellectual property for integration into an IC platform environment | United States of America | Lapsed | 2006-09-05 | 2004-04-14 | 7103858 | 10824509 |
| Method and apparatus for verifying the post-optical proximity corrected mask wafer image sensitivity to reticle manufacturing errors | United States of America | Lapsed | 2008-01-29 | 2004-03-12 | 7325222 | 10800219 |
| Method and computer program for verifying an incremental change to an integrated circuit design | United States of America | Granted | 2007-05-15 | 2004-04-19 | 7219317 | 10828408 |
| Method of automated repair of crosstalk violations and timing violations in an integrated circuit design | United States of America | Lapsed | 2006-06-13 | 2004-07-28 | 7062737 | 10901841 |
| Method and computer program for management of synchronous and asynchronous clock domain crossing in integrated circuit design | United States of America | Lapsed | 2008-08-12 | 2004-06-02 | 7412678 | 10859874 |
| Technique for measurement of programmable termination resistor networks on rapidchip and ASIC devices | United States of America | Lapsed | 2006-09-12 | 2004-09-30 | 7106074 | 10954907 |
| Three-dimensional interconnect resistance extraction using variational method | United States of America | Granted | 2007-06-19 | 2005-01-10 | 7234122 | 11032720 |
| Method for calculating frequency-dependent impedance in an integrated circuit | United States of America | Lapsed | 2008-02-19 | 2004-09-21 | 7332917 | 10946422 |
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| Apparatus And Method For Reduced-Order Modeling Of Time-Varying Systems And Computer Storage Medium Containing The Same | United States of America | Lapsed | 2004-02-03 | 1998-09-01 | 6687658 | 09144799 |
| Method For Identifying Untestable Faults In Logic Circuits | United States of America | Expired | 1996-10-15 | 1994-09-14 | 5566187 | 08306088 |
| Process and apparatus for placement of megacells in ICs design | United States of America | Lapsed | 2006-09-05 | 2003-11-21 | 7103865 | 10719393 |
| Automatic Recognition of an Optically Periodic Structure in an Integrated Circuit Design | European Patent | Application | | 2003-06-13 | | 030133243 |
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| Placement of a clock signal supply network during design of integrated | | | | | | |
| System for yield enhancement in programmable logic | United States of America | Lapsed | 2004-11-30 | 2003-08-15 | 6825688 | 10641799 |
| Gate reuse methodology for diffused cell-based IP blocks in platformbased silicon products | United States of America | Lapsed | 2006-06-13 | 2003-10-29 | 7062739 | 10696105 |
| First time silicon and proto test cell notification | United States of America | Lapsed | 2006-04-11 | 2003-09-10 | 7028276 | 10659138 |
| Insertion Of Test Points In RTL Designs | United States of America | Granted | 2001-10-09 | 1998-11-24 | 6301688 | 09199018 |
| Rate Equation Method And Apparatus For Simulation Of Current In A MOS Device | United States of America | Granted | 2002-12-10 | 1999-11-03 | 6493848 | 09433702 |
| System and Method for Debugging System-On-Chips Using Single Or N-Cycle Stepping | United States of America | Lapsed | 2006-05-30 | 2003-12-29 | 7055117 | 10748068 |
| Method for providing clock-net aware dummy metal using dummy regions | United States of America | Granted | 2006-02-28 | 2003-07-31 | 7007259 | 10632622 |
| User Interface Software Development Tool and Method for Enhancing the Sequencing of Instructions within a Superscalar Microprocessor Pipeline by Displaying and Manipulating Instructions in the Pipeline | United States of America | Lapsed | 2010-04-20 | 2003-09-19 | 7703076 | 10664636 |
| Method and apparatus of IC implementation based on C++ language description | United States of America | Lapsed | 2006-07-25 | 2003-07-17 | 7082593 | 10621737 |
| Method and apparatus for finding optimal unification substitution for formulas in technology library | United States of America | Lapsed | 2006-02-21 | 2003-11-21 | 7003739 | 10719787 |
| Device And Method For Parallel Simulation Task Generation And Distribution | United States of America | Granted | 2002-02-05 | 1998-08-24 | 6345240 | 09138702 |
| VDD over and undervoltage measurement techniques using monitor cells | United States of America | Lapsed | 2006-02-21 | 2003-11-03 | 7003421 | 10700790 |
| Method of clock driven cell placement and clock tree synthesis for integrated circuit design | United States of America | Granted | 2006-05-02 | 2003-08-27 | 7039891 | 10650296 |
| Boundary Scan Chain Routing | United States of America | Lapsed | 2003-10-28 | 2000-08-07 | 6640324 | 09633795 |
| Low-Displacement Rank Preconditioners For Simplified Non-Linear Analysis Of Circuits And Other Devices | United States of America | Granted | 2001-01-30 | 1997-11-20 | 6182270 | 08975250 |
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| United States of America Flexible design for memory use in integrated circuits |
| United States of America operating parameters |
| System and method for achieving timing closure in fixed placed designs United States of America after implementing logic changes |
| Advanced design format library for integrated circuit design synthesis of America and floorplanning tools |
| United States of America Method and apparatus for implementing engineering change orders |
| Method and apparatus for exposing pre-diffused IP blocks in a United States of America semiconductor device for prototyping based on hardware emulation |
| United States of America Delay |
| United States of America Decoupling capacitance estimation and insertion flow for ASIC designs |
| United States of America Method And Apparatus For Testing Long Counters |
| United States of America Method And Apparatus For Pseudorandom Boundary-Scan Testing |
| United States of America Timing |
| United States of America Method of routing a redistribution layer trace in an integrated circuit die |
| United States of America Increasing Testability By Clock Transformation |
| Assuring United States of America Platform |
| United States of America Integrated circuits, and design and manufacture thereof |
| Method of sizing via arrays and interconnects to reduce routing United States of America congestion in flip chip integrated circuits |
| Method And Apparatus For Efficient Design And Analysis Of Integrated United States of America |
| Method and Apparatus for Determining The Reachable States in A United States of America Hybrid Model State Machine |
| United States of America Device And Method For Parallel Simulation |
| Method and Apparatus for Generating Conformance Test Data United States of America Sequences |
| United States of America Process skew results for integrated circuits |
| United States of America Speed-Signaling Testing For Integrated Circuits |
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| Method of delay calculation for variation in interconnect metal process | United States of America | Lapsed | 2005-04-12 | 2002-10-16 | 6880142 | 10272182 |
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| Placement of configurable input/output buffer structures during design of integrated circuits | United States of America | Lapsed | 2004-11-23 | 2002-12-31 | 6823502 | 10334568 |
| Designing and testing the interconnection of addressable devices of integrated circuits | United States of America | Lapsed | 2005-10-25 | 2003-06-19 | 6959428 | 10465186 |
| Method And Apparatus For Efficient Design And Analysis Of Integrated Circuits Using Multiple Time Scales | Japan | Granted | 2001-11-22 | 1998-01-27 | 3253910 | 10014642 |
| Chip management system | United States of America | Lapsed | 2006-04-04 | 2002-11-20 | 7024636 | 10301182 |
| integrated circuit design | United States of America | Lapsed | 2006-06-13 | 2003-09-17 | 7062731 | 10665927 |
| Method of noise analysis and correction of noise violations for an | | | | | | |
| Length matrix generator for register transfer level code | United States of America | Lapsed | 2004-06-29 | 2002-12-31 | 6757885 | 10334570 |
| Optimizing depths of circuits for Boolean functions | United States of America | Lapsed | 2006-09-05 | 2002-11-12 | 7103868 | 10291982 |
| Parallel configurable IP design methodology | United States of America | Lapsed | 2004-08-24 | 2002-10-15 | 6782523 | 10271026 |
| products | United States of America | Lapsed | 2005-07-26 | 2002-12-13 | 6922823 | 10318639 |
| Method for creating derivative integrated circuit layouts for related | | | | | | |
| Process of restructuring logics in ICs for setup and hold time optimization | United States of America | Lapsed | 2004-10-26 | 2002-09-25 | 6810515 | 10254380 |
| Process layout of buffer modules in integrated circuits | United States of America | Lapsed | 2004-07-06 | 2002-09-25 | 6760896 | 10254607 |
| proximity correction | United States of America | Lapsed | 2006-08-15 | 2002-12-20 | 7093228 | 10327304 |
| Method and system for classifying an integrated circuit for optical | | | | | | |
| Sidelobe correction for attenuated phase shift masks | United States of America | Lapsed | 2005-06-28 | 2002-12-20 | 6911285 | 10327451 |
| optical proximity correction | United States of America | Lapsed | 2005-05-24 | 2002-12-20 | 6898780 | 10327314 |
| Method and system for constructing a hierarchy-driven chip covering for | | | | | | |
| Net segment analyzer for chip CAD layout | United States of America | Lapsed | 2004-11-09 | 2003-01-22 | 6817004 | 10349564 |
| chip resources for manufacturing tests | United States of America | Lapsed | 2005-03-22 | 2003-06-11 | 6871154 | 10459158 |
| Method and apparatus for automatically configuring and/or inserting | | | | | | |
| Boundary Scan Chain Routing | Japan | Granted | 2006-11-10 | 2001-08-07 | 3876380 | 2001238546 |
| Rate Equation Method And Apparatus For Simulation Of Current In A MOS Device | Japan | Lapsed | 2012-05-11 | 2000-11-02 | 4988981 | 2000335373 |
| Congestion estimation for register transfer level code | United States of America | Lapsed | 2005-06-14 | 2002-12-31 | 6907588 | 10334743 |
| Method to find boolean function symmetries | United States of America | Lapsed | 2005-03-15 | 2002-11-19 | 6868536 | 10299564 |
| Isolation Stress and Optical Proximity Effects | Korea, Republic of (KR) | Lapsed | 2011-12-16 | 2005-11-18 | 10-1097710 | 1020050110790 |
| Method Of Making A Semiconductor Device By Balancing Shallow Trench | | | | | | |
| Netlist redundancy detection and global simplification | United States of America | Lapsed | 2005-01-25 | 2002-12-31 | 6848094 | 10334731 |
| Method for generating tech-library for logic function | United States of America | Lapsed | 2006-06-13 | 2003-04-30 | 7062726 | 10426549 |
| Method for combining states | United States of America | Lapsed | 2005-09-20 | 2002-12-19 | 6948139 | 10326717 |
| Optical proximity correction method using weighted priorities | United States of America | Lapsed | 2006-06-27 | 2003-06-03 | 7069535 | 10453182 |
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| Effective approximated calculation of smooth functions | United States of America | Lapsed | 2004-03-02 | 2002-12-03 | 6701499 | 10308557 |
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| Blocked net buffer insertion | United States of America | Granted | 2003-09-02 | 2002-03-06 | 6615401 | 10092195 |
| Automatic recognition of an optically periodic structure in an integrated circuit design | United States of America | Lapsed | 2004-08-31 | 2002-08-21 | 6785871 | 10225909 |
| Table module compiler equivalent to ROM | United States of America | Lapsed | 2006-02-21 | 2002-06-19 | 7003510 | 10177591 |
| Method of decreasing instantaneous current without affecting timing | United States of America | Lapsed | 2004-09-21 | 2002-10-21 | 6795954 | 10278150 |
| Contact ring architecture | United States of America | Lapsed | 2004-01-27 | 2002-05-08 | 6683476 | 10140967 |
| Modeling delays for small nets in an integrated circuit design | United States of America | Granted | 2003-07-01 | 2001-05-15 | 6587999 | 09859149 |
| Spanning tree method for K-dimensional space | United States of America | Lapsed | 2003-12-16 | 2002-05-22 | 6665850 | 10153570 |
| Calculating resistance of conductor layer for integrated circuit design | United States of America | Lapsed | 2004-10-05 | 2002-08-19 | 6802047 | 10224019 |
| Chip design method for designing integrated circuit chips with embedded memories | United States of America | Lapsed | 2004-08-10 | 2002-05-22 | 6775811 | 10151826 |
| Collaborative integration of hybrid electronic and micro and sub-micro level aggregates | United States of America | Lapsed | 2006-03-21 | 2002-04-30 | 7016748 | 10135869 |
| Method of using filler metal for implementing changes in an integrated circuit design | United States of America | Granted | 2004-06-08 | 2002-08-30 | 6748579 | 10231904 |
| Instantaneous Voltage Drop Sensitivity Analysis Tool (IVDSAT) | United States of America | Lapsed | 2010-10-19 | 2002-06-19 | 7818157 | 10174681 |
| Scale-invariant topology and traffic allocation in multi-node system-on-chip switching fabrics | United States of America | Lapsed | 2004-07-27 | 2002-06-27 | 6769097 | 10185740 |
| Wafer process critical dimension, alignment, and registration analysis simulation tool | United States of America | Lapsed | 2004-08-24 | 2002-09-05 | 6782525 | 10236207 |
| Device parameter and gate performance simulation based on wafer image prediction | United States of America | Lapsed | 2004-08-10 | 2002-08-20 | 6775818 | 10223931 |
| Custom clock interconnects on a standardized silicon platform | United States of America | Lapsed | 2005-06-21 | 2003-09-17 | 6910201 | 10664137 |
| Rapid prototyping system | United States of America | Granted | 2007-11-20 | 2002-08-30 | 7299427 | 10231643 |
| Interface for rapid prototyping system | United States of America | Granted | 2007-05-01 | 2002-08-30 | 7212961 | 10231641 |
| Bent gate transistor modeling | United States of America | Lapsed | 2005-03-22 | 2002-10-07 | 6871333 | 10265803 |
| Automation of the development, testing, and release of a flow framework and methodology to design integrated circuits | United States of America | Lapsed | 2006-03-28 | 2003-05-08 | 7020852 | 10435168 |
| Method for improving OPC modeling | United States of America | Lapsed | 2005-08-23 | 2003-01-13 | 6934929 | 10341119 |
| Model of the contact region of integrated circuit resistors | United States of America | Lapsed | 2004-03-02 | 2002-09-23 | 6701495 | 10253006 |
| Estimating free space in IC chips | United States of America | Lapsed | 2004-06-29 | 2002-12-11 | 6757883 | 10316594 |
| Apparatus and method for visualizing and analyzing resistance networks | United States of America | Lapsed | 2005-02-08 | 2002-12-30 | 6854103 | 10331521 |
| Method Of Making A Semiconductor Device By Balancing Shallow Trench Isolation Stress and Optical Proximity Effects | Japan | Lapsed | 2013-10-04 | 2005-11-18 | 5378636 | 2005333495 |
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| Method For Inserting Test Points For Full- And Partial-Scan Built-In Self- Testing | United States of America | Expired | 1998-10-27 | 1997-09-29 | 5828828 | 08939498 |
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| A Method For Identifying Cyclicity In Circuit Designs | Japan | Lapsed | 2006-09-01 | 2006-02-22 | 3847774 | 2006045368 |
| Method and apparatus for automatic marking of integrated circuits in wafer scale testing | United States of America | Lapsed | 2004-09-07 | 2001-11-05 | 6788091 | 09993015 |
| Method and apparatus for implementing a metamethodology | United States of America | Lapsed | 2006-02-14 | 2001-11-20 | 6999910 | 10015194 |
| Method to debug IKOS method | United States of America | Lapsed | 2004-02-10 | 2001-12-27 | 6691288 | 10034535 |
| circuit | United States of America | Granted | 2002-04-09 | 1998-12-08 | 6370492 | 09207878 |
| Modified design representation for fast fault simulation of an integrated | | - | | | | |
| Distributed delay prediction of multi-inimon gate deep sub-inicion Asic designs | United States of America | Lapsed | 2006-02-28 | 2001-11-29 | 7006962 | 09997888 |
| Testing synchronization circuitry using digital simulation | United States of America | Granted | 2002-03-05 | 1998-04-01 | 6353906 | 09053833 |
| System and method for designing an integrated circuit | United States of America | Granted | 2004-09-14 | 2001-10-30 | 6792584 | 10021619 |
| division | United States of America | Lapsed | 2003-11-11 | 2001-11-08 | 6647538 | 10045473 |
| Apparatus and method for signal skew characterization utilizing clock | | | | | | |
| Revision Control for Database of Evolved Design | United States of America | Lapsed | 2009-05-26 | 2002-05-10 | 7539680 | 10143155 |
| Cell pin extensions for integrated circuits | United States of America | Lapsed | 2003-03-18 | 2000-12-13 | 6536027 | 09735837 |
| design | United States of America | Lapsed | 2004-07-27 | 2001-12-03 | 6769107 | 10005062 |
| Method and system for implementing incremental change to circuit | | | | | | |
| System real-time analysis tool | United States of America | Lapsed | 2006-05-09 | 2002-02-15 | 7043718 | 10077066 |
| Integrated circuit having integrated programmable gate array and field programmable gate array, and method of operating the same | United States of America | Granted | 2005-06-07 | 2002-03-25 | 6904586 | 10105579 |
| Integrated circuit having a programmable gate array and a field programmable gate array and methods of designing and manufacturing the same using testing IC before configuring FPGA | United States of America | Lapsed | 2006-04-04 | 2002-04-10 | 7024641 | 10119821 |
| Method of repeater insertion for hierarchical integrated circuit design | United States of America | Granted | 2003-12-09 | 2002-02-27 | 6662349 | 10086232 |
| Developement of hardmac technology files (CLF, tech and synlib) for RTL and full gate level netlists | United States of America | Granted | 2003-12-02 | 2001-12-19 | 6658628 | 10025123 |
| Automated analysis of RTL code containing ASIC vendor rules | United States of America | Lapsed | 2006-07-25 | 2003-04-30 | 7082584 | 10427609 |
| Floor plan tester for integrated circuit design | United States of America | Lapsed | 2004-03-02 | 2002-03-27 | 6701493 | 10109113 |
| Power routing with obstacles | United States of America | Lapsed | 2004-06-29 | 2002-01-29 | 6757881 | 10059480 |
| Device under interface card with on-board testing | United States of America | Lapsed | 2004-06-08 | 2002-09-23 | 6747473 | 10252488 |
| Design and optimization methods for integrated circuits | United States of America | Lapsed | 2005-08-16 | 2002-05-15 | 6931612 | 10146363 |
| | United States of America | Granted | 2005-09-20 | 2002-04-25 | 6948114 | 10132360 |
| Multidirectional router | United States of America | Lapsed | 2005-01-18 | 2001-12-20 | 6845495 | 10027642 |
| Application of co-verification tools to the testing of IC designs | United States of America | Granted | 2005-01-11 | 2002-06-24 | 6842883 | 10178193 |
| Clock tree synthesis with skew for memory devices | United States of America | Lapsed | 2005-09-06 | 2002-10-21 | 6941533 | 10277398 |
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| Flip chip trace library generator | United States of America | Granted | 2003-02-25 | 2001-01-08 | 6526540 | 09756506 |
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| Method and apparatus for locating constants in combinational circuits | United States of America | Lapsed | 2003-03-18 | 2000-07-27 | 6536016 | 09626037 |
| Method and apparatus for detecting equivalent and anti-equivalent pins | United States of America | Granted | 2003-03-04 | 2000-10-02 | 6530063 | 09677276 |
| Method and apparatus for quick search for identities applicable to specified formula | United States of America | Granted | 2003-10-21 | 2000-10-02 | 6637011 | 09677940 |
| Method of datapath cell placement for bitwise and non-bitwise integrated circuit designs | United States of America | Granted | 2003-05-06 | 2001-03-29 | 6560761 | 09823184 |
| Method for minimizing clock skew by relocating a clock buffer until clock skew is within a tolerable limit | United States of America | Granted | 2004-04-20 | 2000-12-11 | 6725389 | 09734539 |
| Method and apparatus for dynamic buffer and inverter tree optimization | United States of America | Lapsed | 2004-01-20 | 2000-10-02 | 6681373 | 09678478 |
| Method and apparatus for timing driven resynthesis | United States of America | Granted | 2003-05-13 | 2000-10-02 | 6564361 | 09677475 |
| Placement-based integrated circuit re-synthesis tool using estimated maximum interconnect capacitances | United States of America | Granted | 2003-04-08 | 2001-02-20 | 6546541 | 09789108 |
| I/O device layout during integrated circuit design | United States of America | Granted | 2002-09-24 | 2000-01-26 | 6457157 | 09492881 |
| Spare cells placement methodology | United States of America | Granted | 2002-09-03 | 2000-01-28 | 6446248 | 09493467 |
| Full-chip extraction of interconnect parasitic data | United States of America | Granted | 2002-10-08 | 2001-03-14 | 6463571 | 09808549 |
| Method of datapath cell placement for an integrated circuit | United States of America | Granted | 2002-12-17 | 2001-03-13 | 6496967 | 09805642 |
| Pin placement method for integrated circuits | United States of America | Granted | 2002-09-10 | 2000-11-30 | 6449760 | 09727426 |
| Cycle modeling in cycle accurate software simulators of hardware modules for software/software cross-simulation and hardware/software co-simulation | United States of America | Granted | 2003-09-23 | 1999-12-22 | 6625572 | 09470362 |
| Programmable ASIC | United States of America | Granted | 2003-07-01 | 1999-12-16 | 6588006 | 09464623 |
| Cell interconnect delay library for integrated circuit design | United States of America | Granted | 2003-03-11 | 2001-03-07 | 6532576 | 09801392 |
| Pseudo-random one-to-one circuit synthesis | United States of America | Lapsed | 2006-05-23 | 2001-06-18 | 7050582 | 09883733 |
| Netlist resynthesis program using structure co-factoring | United States of America | Granted | 2003-04-08 | 2000-12-14 | 6546539 | 09736571 |
| Netlist resynthesis program based on physical delay calculation | United States of America | Lapsed | 2003-04-29 | 2000-12-14 | 6557144 | 09737239 |
| Verilog to vital translator | United States of America | Lapsed | 2003-12-23 | 2001-10-31 | 6668359 | 10003823 |
| Method and apparatus for custom design in a standard cell design environment | United States of America | Lapsed | 2005-05-24 | 2002-05-09 | 6898767 | 10144101 |
| Integrated design system and method for reducing and avoiding crosstalk | United States of America | Granted | 2003-07-15 | 2001-11-13 | 6594805 | 09986912 |
| Web based OLA memory generator | United States of America | Lapsed | 2006-05-23 | 2001-10-09 | 7051318 | 09973153 |
| Method For Identifying Untestable & Dequential Logic Circuits | United States of America | Expired | 1996-09-24 | 1996-02-09 | 5559811 | 08599289 |
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| System And Method For Reducing The Generation Of Inconsequential Prica Violations Resulting From Timing Analyses | United States of America | Granted | 2011-06-28 | 2008-08-13 | 7971169 | 12190784 |
| Integrated circuit design system and method for reducing and avoiding crosstalk | United States of America | Lapsed | 2005-06-14 | 2001-10-02 | 6907590 | 09968008 |
| rica Pulse rejection circuit model program and technique in VHDL | United States of America | Granted | 2000-10-31 | 1998-03-25 | 6141631 | 09047877 |
| erica Optimized metal stack strategy | United States of America | Granted | 2003-07-01 | 2001-08-28 | 6587991 | 09941359 |
| rica Test bench interface generator for tester compatible simulations | United States of America | Expired | 1999-10-26 | 1997-06-17 | 5974241 | 08877117 |
| rica Metastability risk simulation analysis tool and method | United States of America | Granted | 2002-06-18 | 1999-01-20 | 6408265 | 09233529 |
| Extractor and schematic viewer for a design representation, and exica associated method | United States of America | Granted | 2001-08-07 | 1998-09-11 | 6272671 | 09151900 |
| Cell placement in integrated circuit chips to remove cell overlap, row overflow and optimal placement of dual height cells | United States of America | Granted | 2003-09-30 | 2001-09-19 | 6629304 | 09955698 |
| rica RTL annotation tool for layout induced netlist changes | United States of America | Granted | 2003-03-04 | 2001-04-30 | 6530073 | 09847838 |
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| rica Timing driven interconnect analysis | United States of America | Granted | 2003-03-11 | 2001-06-27 | 6532577 | 09894618 |
| rica Simulation format creation system and method | United States of America | Granted | 2002-04-09 | 1998-09-10 | 6370493 | 09151228 |
| rica Iterative prediction of circuit delays | United States of America | Granted | 2002-09-24 | 2000-06-13 | 6457160 | 09592749 |
| Automated design method and system for synthesizing digital multipliers | United States of America | Expired | 2000-05-23 | 1996-04-10 | 6066178 | 08630257 |
| erica Input/output characterization chain for an integrated circuit | United States of America | Lapsed | 2006-04-11 | 2002-04-18 | 7028238 | 10125675 |
| rica Long path at-speed testing | United States of America | Lapsed | 2006-06-20 | 2001-12-05 | 7065683 | 10011796 |
| Method of automatically generating schematic and waveform diagrams for analysis of timing margins and signal skews of relevant logic cells using input signal predictors and transition times | United States of America | Granted | 2002-08-27 | 2000-10-06 | 6442741 | 09680893 |
| Method for programming an FPGA and implementing an FPGA interconnect | United States of America | Granted | 2002-08-13 | 1999-12-16 | 6434735 | 09464741 |
| Automated system for inserting and reading of probe points in silicon embedded testbenches | United States of America | Lapsed | 2003-11-25 | 2000-04-17 | 6654919 | 09550764 |
| rica Method to translate UDPs using gate primitives | United States of America | Granted | 2003-12-02 | 2000-11-09 | 6658630 | 09710359 |
| rica Standard library generator for cell timing model | United States of America | Granted | 2002-12-17 | 2000-11-17 | 6496962 | 09715814 |
| Method for designing an integrated circuit using predefined and preverified core modules having prebalanced clock trees | United States of America | Granted | 2001-07-10 | 1997-03-07 | 6260175 | 08813340 |
| Method and apparatus for local resynthesis of logic trees with multiple cost functions | United States of America | Granted | 2003-04-01 | 2000-10-02 | 6543032 | 09678479 |
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| Timing Signoff System and Method that Takes Static and Dynamic Voltage Drop into Account | United States of America | Lapsed | 2013-08-20 | 2011-09-27 | 8516424 | 13246102 |
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| Verification of RRAM Tiling Netlist | United States of America | Lapsed | 2008-01-01 | 2004-11-30 | 7315993 | 10999468 |
| Multi-Pass Routing to Reduce Crosstalk | United States of America | Lapsed | 2013-12-10 | 2012-05-09 | 8607180 | 13467696 |
| Method to Derive The Functionality Of A Digital Circuit From Its Mask Layout | United States of America | Expired | 1997-10-14 | 1995-11-03 | 5677848 | 08552421 |
| Generic Interactive Device Model Wrapper | United States of America | Expired | 1998-07-21 | 1996-06-12 | 5784594 | 08664020 |
| Technique For Effectively Routing Conduction Paths In Circuit Layouts | United States of America | Expired | 2000-05-02 | 1996-09-26 | 6058256 | 08720235 |
| Method Of Making An Integrated Circuit Including Noise Modelling And Prediction | United States of America | Expired | 2000-06-06 | 1997-09-23 | 6072947 | 08933733 |
| System And Method For Simulating Electronic Circuits | United States of America | Granted | 2000-11-28 | 1998-07-29 | 6154716 | 09126013 |
| Capacitance Coupling For RC Circuits | United States of America | Granted | 2001-06-26 | 1998-02-26 | 6253355 | 09031012 |
| Method For Fast Estimation Of Step Response Found Due To | | | | | | |
| METHOD AND SYSTEM FOR TESTING MULTIPORT MEMORIES | United States of America | Granted | 2001-04-10 | 1998-10-08 | 6216241 | 09168409 |
| Chip-On-Chip Testing Using BIST | United States of America | Granted | 2002-09-24 | 1999-04-07 | 6456101 | 09287862 |
| Integrated Circuit Testing Using A High Speed Data Interface Bus | United States of America | Granted | 2002-07-30 | 11-80-6661 | 6427216 | 09265932 |
| Deriving Statistical Device Models From Electrical Test Data | United States of America | Granted | 2003-05-06 | 1999-04-12 | 6560568 | 09290321 |
| Method And Apparatus For Matching Capacitance Of Filters Having Different Circuit Topologies | United States of America | Granted | 2003-03-25 | 2000-05-10 | 6539524 | 09567606 |
| Semiconductor Device Manufacturing | United States of America | Granted | 2007-03-27 | 2004-09-29 | 7197723 | 10953480 |
| Circuit Design | United States of America | Lapsed | 2008-10-28 | 2005-07-22 | 7444275 | 11187455 |
| Multi-Variable Polynomial Modeling Techniques For Use In Integrated | | | | | | |
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| Establishing Benchmarks For Analyzing Benefits Associated With Voltage Scaling, Analyzing The Benefits And An Apparatus Therefor | United States of America | Granted | 2012-02-21 | 2009-07-27 | 8122422 | 12510082 |
| System and Method for Clock Optimization to Achieve Timing Signoff in an Electronic Circuit and Electronic Design Automation Tool Incorporating the Same | United States of America | Lapsed | 2012-09-18 | 2009-04-14 | 8271922 | 12423001 |
| Implementing And Checking Electronic Circuits With Flexible Ramptime Limits and Tools For Performing The Same | United States of America | Lapsed | 2012-12-11 | 2010-07-14 | 8332792 | 12836274 |
| Implementing And Checking Electronic Circuits With Flexible Ramptime Limits and Tools For Performing The Same | United States of America | Lapsed | 2014-04-08 | 2012-11-19 | 8694937 | 13681283 |
| Methods and Systems for Performing Timing Sign-Off of an Integrated Circuit Design | United States of America | Lapsed | 2013-07-09 | 2010-10-11 | 8484008 | 12901588 |
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| | FiledDate GrantDate Status 2008-12-31 2012-08-07 Lapsed 2008-12-16 2013-01-08 Lapsed 2008-09-16 2011-10-25 Lapsed 2008-07-30 2013-06-11 Lapsed 2008-05-08 2010-11-30 Granted 2008-05-03 2013-03-12 Lapsed 2008-10-09 2013-03-12 Lapsed 2008-10-09 2013-03-12 Granted 2008-04-25 2010-12-14 Granted 2008-04-16 2011-02-22 Granted 2007-09-04 2011-02-22 Granted | GrantDate Status 1 2012-08-07 Lapsed 16 2013-01-08 Lapsed 16 2011-10-25 Lapsed 18 2011-08-30 Granted 19 2013-06-11 Lapsed 2010-11-30 Granted 2013-03-12 Lapsed 2013-03-12 Lapsed 2013-03-12 Granted 2011-02-22 Granted 2011-02-22 Granted |
| | 4834 | 8464202 201 |
| 8464202 2011-05-24 2013-06-11 Granted | 13367094 | |
| 8464202 2011-05-24 2013-06-11 Granted United States of America Fully P 8522179 2012-02-06 2013-08-27 Lapsed United States of America Integra | 13649909 | 8543951 201 |
| 8464202 2011-05-24 2013-06-11 Granted United States of America System 8522179 2012-02-06 2013-08-27 Lapsed United States of America Integra 8543951 2012-10-11 2013-09-24 Lapsed United States of America Design | 12905301 | 8341573 201 |
| 8464202 2011-05-24 2013-06-11 Granted United States of America System 8522179 2012-02-06 2013-08-27 Lapsed United States of America Integra 8543951 2012-10-11 2013-09-24 Lapsed United States of America Design 8341573 2010-10-15 2012-12-25 Lapsed United States of America Design Novel Levera | 12421481 | 8515695 200 |
| 8464202 2011-05-24 2013-06-11 Granted United States of America 8522179 2012-02-06 2013-08-27 Lapsed United States of America 8543951 2012-10-11 2013-09-24 Lapsed United States of America 8341573 2010-10-15 2012-12-25 Lapsed United States of America 8515695 2009-04-09 2013-08-20 Lapsed United States of America | 12510122 | 8127264 200 |
| 8464202 2011-05-24 2013-06-11 Granted United States of America 8522179 2012-02-06 2013-08-27 Lapsed United States of America 8543951 2012-10-11 2013-09-24 Lapsed United States of America 8341573 2010-10-15 2012-12-25 Lapsed United States of America 8515695 2009-04-09 2013-08-20 Lapsed United States of America 8127264 2009-07-27 2012-02-28 Granted United States of America | 13421710 | 8539419 201 |
| 8464202 2011-05-24 2013-06-11 Granted United States of America 8522179 2012-02-06 2013-08-27 Lapsed United States of America 8543951 2012-10-11 2013-09-24 Lapsed United States of America 8341573 2010-10-15 2012-12-25 Lapsed United States of America 8515695 2009-04-09 2013-08-20 Lapsed United States of America 8127264 2009-07-27 2012-02-28 Granted United States of America 8539419 2012-03-15 2013-09-17 Lapsed United States of America | | |

| Input/Output Buffer Information Specification (IBIS) Model Generation For Multi-Chip Modules (MCM) and Similar Devices | United States of America | Granted | 2012-05-15 | 2006-08-31 | 8180600 | 11469028 |
|--|--------------------------|-----------|------------|------------|----------|---------------|
| Integrated Computer-Aided Circuit Design Kit Facilitating Verification Of Designs Across Different Process Technologies | United States of America | Lapsed | 2008-03-04 | 2004-12-22 | 7340697 | 11019885 |
| Modifying Integrated Circuit Designs To Achieve Multiple Operating Frequency Targets | United States of America | Granted | 2011-04-19 | 2007-03-29 | 7930674 | 11693081 |
| Characterizing Performance Of An Electronic System | United States of America | Lapsed | 2012-08-28 | 2008-05-15 | 8255199 | 12120894 |
| Characterizing Performance of an Electronic System | United States of America | Granted | 2014-03-11 | 2012-07-16 | 8670970 | 13549599 |
| Generating Integrated-Circuit Floorplan Layouts | United States of America | Lapsed | 2012-07-10 | 2009-07-24 | 8219959 | 12508898 |
| Implementation | United States of America | Lapsed | 2010-01-05 | 2007-05-17 | 7644382 | 11749904 |
| Upstream Driver Strength Command-Language-Based Functional Engineering Change Order (ECO) | United States of America | Lapsed | 2009-09-01 | 2006-12-07 | 7584439 | 11567986 |
| Automated liming Optimization | United States of America | Lapsed | 2012-12-18 | 2009-04-09 | 8336012 | 12421198 |
| Electrostatic Discharge Device Verification In An Integrated Circuit | United States of America | Lapsed | 2009-11-10 | 2006-12-14 | 7617467 | 11610825 |
| Granular Channel Width for Power Optimization | Japan | Lapsed | 2014-10-03 | 2010-07-21 | | 2011158945 |
| Granular Channel Width for Power Optimization | European Patent | Abandoned | | 2011-07-21 | | 111747796 |
| Granular Channel Width for Power Optimization | United States of America | Granted | 2012-06-05 | 2010-07-21 | 8196086 | 12840535 |
| Granular Channel Width for Power Optimization | Taiwan | Abandoned | | 2011-07-19 | | 100125423 |
| Granular Channel Width for Power Optimization | China | Abandoned | | 2011-07-21 | | 201110205798X |
| Granular Channel Width for Power Optimization | Korea, Republic of (KR) | Abandoned | | 2011-07-21 | | 201172482 |
| Method for Estimation of Trace Information Bandwidth Requirements | United States of America | Granted | 2011-05-24 | 2008-06-23 | 7949986 | 12144248 |
| Dual Path Static Timing Analysis | United States of America | Granted | 2011-06-21 | 2008-09-08 | 7966592 | 12206048 |
| A Systematic Benchmarking System And Method For Standardized Data Creation, Analysis And Comparison Of Semiconductor Technology Node Characteristics | United States of America | Lapsed | 2011-09-20 | 2009-02-03 | 8024694 | 12365084 |
| Systematic benchmarking system and method for standardized data creation, analysis and comparison of semiconductor technology node characteristics | United States of America | Lapsed | 2012-11-06 | 2011-08-18 | 8307324 | 13212427 |
| Systematic Benchmarking System And Method For Standardized Data Creation, Analysis And Comparison Of Semiconductor Technology Node Characteristics | United States of America | Lapsed | 2013-09-17 | 2012-10-11 | 8539423 | 13649996 |
| Control Signal Source Replication | United States of America | Granted | 2011-08-16 | 2008-10-01 | 8001497 | 12243768 |
| REDUCING PATH DELAY SENSITIVITY TO TEMPERATURE VARIATION IN TIMING-CRITICAL PATHS | United States of America | Lapsed | 2012-07-17 | 2008-10-14 | 8225257 | 12251110 |
| Design Optimization with Adaptive Body Biasing | United States of America | Granted | 2012-02-07 | 2008-09-29 | 8112734 | 12240210 |
| Hierarchical Design Flow Generator | United States of America | Lapsed | 2014-03-25 | 2013-08-20 | 8683407 | 13971560 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| 09283394 6397 | 09283393 6289298 | 09283392 6324 | 09564438 6732 | 09427238 6871167 | 09408371 6463561 | 09434961 6578 | | 09780861 6728917 | 09866137 6680 | 2003328548 4559 | 10254083 6893 | 1020030065848 10-9 | 92125773 -319 | 03196847 2394 | 092134419 1303717 | 2003426492 4579 | 10335540 7005 | 10880216 7346 | 11198930 7480 | 11376600 7509 | AppNo Pate |
|---|---|---|--------------------------|---|---|--------------------------|---|---|--|---|---|--|---|---|--|--|--|---|---|--|------------|
| 6397171 | | 6324493 | 6732311 | | | 6578175 | | | 6680150 | 4559719 | 6893800 | 10-932081 | -319592 | 2394832 | | 4579531 | 7005873 | 7346879 | 7480874 | 7509609 | PatentNo |
| 1999-04-01 | 1999-04-01 | 1999-04-01 | 2000-05-04 | 1999-10-26 | 1999-09-29 | 1999-11-05 | | 2001-02-09 | 2001-05-25 | 2003-09-19 | 2002-09-24 | 2003-09-23 | 2003-09-18 | 2003-08-21 | 2003-12-05 | 2003-12-24 | 2002-12-31 | 2004-06-29 | 2005-08-05 | 2006-03-15 | FiledDate |
| 2002-05-28 | 2001-09-11 | 2001-11-27 | 2004-05-04 | 2005-03-22 | 2002-10-08 | 2003-06-10 | | 2004-04-27 | 2004-01-20 | 2010-07-30 | 2005-05-17 | 2009-12-08 | 2010-01-11 | 2006-01-25 | 2008-12-01 | 2010-09-03 | 2006-02-28 | 2008-03-18 | 2009-01-20 | 2009-03-24 | GrantDate |
| Granted L | Granted (| Granted | Lapsed | Lapsed | Granted L | Granted L | | Lapsed | Lapsed | Lapsed | Granted L | Granted | Lapsed | Lapsed | Lapsed 1 | | | Lapsed | Lapsed l | Granted (| Status (|
| United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | United States of America | | United States of America | United States of America | Japan | United States of America | Korea, Republic of (KR) | Taiwan | United Kingdom | Taiwan | Japan | United States of America | United States of America | United States of America | United States of America | Country |
| Method And Apparatus For Modeling Electromagnetic Interactions In Electrical Circuit Metalizations To Simulate Their Electrical Characteristics | Method And Apparatus For Quasi Full-Wave Modeling Of Interactions In Circuits | Method And Apparatus For Modeling Electromagnetic Interactions In Electrical Circuit Metalizations To Simulate Their Electrical Characteristics | On-Chip Debugger | System And Method For Determining Capacitance For Large-Scale Integrated Circuits | Almost Full-Scan BIST Method And System Having Higher Fault Coverage And Shorter Test | Chip Designs | Method And Apparatus For Evaluating And Correcting Errors In Integrated Circuit | Sequential Test Pattern Generation Using Combinational Techniques | Proximity Correction Using Shape Engineering | SubstrateTopography Comensation at Mask Design: 3D OPC Topography Anchored. | SubstrateTopography Comensation at Mask Design: 3D OPC Topography Anchored. | SubstrateTopography Comensation at Mask Design: 3D OPC Topography Anchored | Substrate Topography Comensation at Mask Design: 3D OPC Topography Anchored | SubstrateTopography Comensation at Mask Design: 3D OPC Topography Anchored. | Built-In Self-Test Hierarchy For An Integrated Circuit | Built-In Self-Test Hierarchy For An Integrated Circuit | Built-In Self-Test Hierarchy For An Integrated Circuit | Symmetric Signal Distribution Through Abutment Connection | Reliability Analysis Of Integrated Circuits | Methods And Apparatus For Reducing Timing Skew | Title |

| Fault Simulator For Digital Circuitry | United States of America | Expired | 1999-04-20 | 1997-04-15 | 5896401 | 08843427 |
|---|--------------------------|---------|------------|------------|----------|----------|
| Systems And Methods For Testing And Manufacturing Large-Scale, Transistor-Based Nonlinear Circuits | United States of America | Expired | 1999-07-27 | 1997-04-30 | 5930153 | 08845963 |
| Systems And Methods For Determining Characteristics Of A Singular Circuit | United States of America | Expired | 1998-12-01 | 1997-04-29 | 5844821 | 08841298 |
| Method For Built-In Self-Testing Of Ring-Address FIFOS Having A Data Input Register With Transparent Latches | United States of America | Expired | 1999-11-02 | 1997-10-08 | 5978935 | 08947136 |
| Optimized Built-In Self-Test Method And Apparatus For Random Access Memories | United States of America | Expired | 2001-03-20 | 1997-06-02 | 6205564 | 08867351 |
| Circuit Simulation With Improved Circuit Partitioning | United States of America | Granted | 2001-10-30 | 1997-12-05 | 6311146 | 08985975 |
| Built-In Self Test Architecture For Detecting Path-Delay Faults in a Sequential Circuit | United States of America | Granted | 2000-11-14 | 1998-02-12 | 6148425 | 09022759 |
| Built-In Self-Test Circuit For Read Channel Device | United States of America | Granted | 2000-12-19 | 1998-07-22 | 6163865 | 09120396 |
| A Method For Optimizing Test Fixtures To Minimize Vector Load Time For Automated Test Equipment | United States of America | Granted | 2001-01-02 | 1998-07-27 | 6170071 | 09123380 |
| A Hybrid Algorithm For Test Point Selection For Scan-Based BIST | United States of America | Granted | 2001-07-03 | 1998-06-15 | 6256759 | 09097488 |
| Method For Testing Path Delay Faults In Sequential Logic Circuits | United States of America | Granted | 2000-05-16 | 1998-04-13 | 6065145 | 09058839 |
| A Method For Implementing A BIST Scheme Into Integrated Circuits For Testing RTL Controller-Data Paths In The Integrated Circuits | United States of America | Granted | 2002-10-08 | 1999-06-23 | 6463560 | 09338338 |
| System And Method For Detecting Faults In Computer Memories Using A Look Up Table | United States of America | Granted | 2001-11-13 | 1998-10-13 | 6317846 | 09170351 |
| Built-In-Self-Test And Self-Repair Methods And Devices For Computer Memories Comprising A Reconfiguration Memory Device | United States of America | Granted | 2002-05-28 | 1998-10-13 | 6397349 | 09170353 |
| Apparatus And Method For Analyzing Circuits Using Reduced-Order Modeling Of Large Linear Subcircuits | United States of America | Granted | 2000-02-08 | 1999-01-29 | 6023573 | 09240432 |
| A Method And Apparatus For Partitioning Long Scan Chains In Scan- Based BISTArchitecture | United States of America | Granted | 2002-04-09 | 1998-10-29 | 6370664 | 09182543 |
| System And Method For Testing Of Embedded Processor | United States of America | Granted | 2000-10-10 | 1998-08-27 | 6131174 | 09140564 |
| An Arrangement For Fault Detection In Circuit Interconnections | United States of America | Granted | 2000-12-26 | 1998-11-23 | 6167542 | 09197977 |
| Method For Self-Testing Integrated Circuits | United States of America | Granted | 2002-03-26 | 1999-04-13 | 6363506 | 09291448 |
| System And Method For Testing An Integrated Circuit Device Using FFT Analysis Based On A Non\(milterative FFT Coherency Analysis Algorithm | United States of America | Granted | 2003-04-08 | 1999-07-09 | 6545454 | 09350645 |
| Method And Apparatus For Modeling Electromagnetic Interactions In Electrical Circuit Metalizations To Simulate Their Electrical Chacteristics | United States of America | Granted | 2002-04-02 | 1999-04-01 | 6367053 | 09283395 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

| and Removal | United States of America | Expired | 1996-12-24 | 1994-04-22 | 5587919 | 08233791 |
|---|--------------------------|---------|------------|------------|----------|----------|
| Apparatus and Method for Logic Optimization by Redundancy Addition | | | | | | |
| Method For Built-In Self-Testing Of Ring-Address FIFOs | United States of America | Expired | 1996-04-30 | 1994-12-28 | 5513318 | 08365394 |
| Method And Apparatus For Testing Large Embedded Counters | United States of America | Expired | 1995-12-05 | 1994-12-28 | 5473651 | 08365264 |
| Built In Self Test Method and Apparatus for Booth Multipliers | United States of America | Expired | 1999-09-28 | 1996-08-09 | 5960009 | 08694881 |
| Method And Apparatus For Built-In Self-Test With Multiple Clock Circuits | United States of America | Expired | 1997-10-21 | 1995-10-20 | 5680543 | 08546055 |
| Simulation Model Using Object-Oriented Programming | United States of America | Expired | 2000-04-25 | 1997-05-31 | 6053947 | 08866937 |
| Applications | United States of America | Expired | 2000-08-22 | 1997-07-28 | 6108807 | 08901250 |
| Apparatus And Method For Hybrid Pin Control Of Boundary Scan | | | | | | |
| Measurements | United States of America | Expired | 1998-12-01 | 1997-07-30 | 5845233 | 08902997 |
| Method And Apparatus For Calibrating Timing Analyzer Path Delay | | | | | | |
| Maintenance Registers With Boundary Scan Interface | United States of America | Expired | 2000-04-18 | 1997-10-31 | 6052808 | 08962340 |
| Fast Transient Circuit Simulation Of Electronic Circuits Including A Crystal | United States of America | Expired | 2000-02-08 | 1997-08-04 | 6023576 | 08905540 |
| Apparatus And Method For Analyzing Circuits Using Reduced-Order Modeling OfLarge Passive Linear Subcircuits | United States of America | Expired | 2000-03-21 | 1997-07-31 | 6041170 | 08904233 |
| Method Of Modeling And Analyzing Electronic Noise Using Pade Approximation-Based Model-Reduction Techniques | United States of America | Granted | 2000-10-24 | 1998-03-09 | 6135649 | 09036846 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |

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| Method for Making A Metal to metal Capacitor | United States of America | Expired | 1996-11-19 | 1994-12-09 | 5576240 | 08353015 |
|--|---|-------------|--------------------|------------|-----------|---------------|
| Within an Integrated Circuit | Korea, Republic of (KR) | Granted | 2000-11-10 | 1998-08-12 | 280565 | 9832710 |
| A Device and Method of Forming A Metal To Metal Capacitor | | | | | | |
| A Device and Method of Forming A Metal To Metal Capacitor Within an Integrated Circuit | Japan | Granted | 2002-06-21 Granted | 1998-08-12 | 3321101 | 10227743 |
| Method For Making A Capacitor | United States of America | Expired | 1998-12-22 | 1996-05-09 | 5851870 | 08644086 |
| Integrated Circuit Capacitor | United States of America | Expired | 1997-08-05 | 1995-06-06 | 5654581 | 08472033 |
| An Electronic Component For An Integrated Circuit | United States of America | Expired | 1998-10-20 | 1997-05-27 | 5825073 | 08863713 |
| Within an Integrated Circuit | United States of America | Expired | 2000-03-21 | 1997-08-12 | 6040616 | 08909563 |
| Method for Making & Metal to Heral Capacitor | | Abandoned | | 1995-12-04 | | 111707156 |
| Method for Making A Metal to metal Capacitor | e | Abandoned | | 1995-11-28 | | 953085156 |
| Method for Making A Metal to metal Capacitor | Germany (Federal Republic of) | Abandoned | | 1995-11-28 | | 953085156 |
| Method for Making A Metal to metal Capacitor | United Kingdom | Abandoned | | 1995-11-28 | | 953085156 |
| Method for Making A Metal to metal Capacitor | Italy | Abandoned | | 1995-11-28 | | 953085156 |
| Method for Making A Metal to metal Capacitor | Japan | Lapsed | 2004-12-03 | 1995-12-08 | 3623569 | 7319840 |
| Method for Making A Metal to metal Capacitor | Korea, Republic of (KR) | Lapsed | 2000-09-04 | 1995-12-08 | 273609 | 9547844 |
| Method for Making A Metal to metal Capacitor | Netherlands | Abandoned | | 1995-11-28 | | 953085156 |
| Method for Making A Metal to metal Capacitor | Spain | Abandoned | | 1995-11-28 | | 953085156 |
| Method for Making A Metal to metal Capacitor | Taiwan | Expired | 1996-08-29 | 1995-03-14 | NI-078045 | 84102411 |
| Connecting The Heatspreader | United States of America | Granted | 2000-09-12 | 1998-11-17 | 6118177 | 09193832 |
| Heatspreader For A Flip Chip Device, And Method For | | | | | | |
| Connecting The Heatspreader | Taiwan | Lapsed | 2001-04-11 Lapsed | 1999-11-26 | NI-131285 | 88120078 |
| Heatspreader For A Flip Chip Device, And Method For | | | | | | |
| Connecting The Heatspreader | Korea, Republic of (KR) | Granted | 2006-12-21 Granted | 1999-11-10 | 662218 | 1019990049683 |
| Heatspreader For A Flip Chip Device, And Method For | | | | | | |
| Connecting The Heatspreader | Japan | Application | | 1999-11-16 | | 11326032 |
| Heatspreader For A Flip Chip Device And Method For | 0 | | | 100011111 | | |
| Connecting The Heatenreader | | Ahandoned | | 1000 11 17 | | 99056657 |
| Hopewarder for A filis Obis Decise And Method for | | | 7007 01 47 | 2000 02 02 | 2011000 | 07770707 |
| Heatspreader For A Flip\(miChip Device And Method For Connecting The Heatspreader | United States of America | | 2004-01-27 | 2000-02-02 | 6681487 | 09/06/09/0 |
| Colliecting the degraphedder | Japan | rapsed | | 2004-06-14 | | 40041/3034 |
| Heatspreader For A Flip Chip Device, And Method For | | - | | | | |
| Flip chip bump distribution on die | United States of America | Expired | 1999-09-14 | 1996-11-12 | 5952726 | 08747325 |
| Method for distributing connection pads on a semiconductor die | United States of America | Expired | 1999-03-23 | 1997-08-14 | 5885855 | 08909312 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |
| | | | | | | |

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| AppNo | PatentNo | FiledDate | GrantDate | Status | Country | Title |
|---------------|----------|------------|--------------------|-----------|-------------------------------|--|
| 60115841 | | 1999-01-13 | | Expired | United States of America | Use Of Novel Barriers For Ta205 As Gate Capacitor Applications |
| 3001583 | | 2000-01-11 | | Abandoned | France | Diffusion Barrier For Use With High Dielectric Constant Materials And Electronic Devices Incorporating Same |
| 3001583 | | 2000-01-11 | | Abandoned | United Kingdom | Diffusion Barrier For Use With High Dielectric Constant Materials And Electronic Devices Incorporating Same |
| 2000004077 | | 2000-01-12 | | Abandoned | Japan | Diffusion Barrier For Use With High Dielectric Constant Materials And Electronic Devices Incorporating Same |
| 3001583 | | 2000-01-11 | | Abandoned | Germany (Federal Republic of) | Diffusion Barrier For Use With High Dielectric Constant Materials And Electronic Devices Incorporating Same |
| 20000001552 | | 2000-01-13 | | Abandoned | Korea, Republic of (KR) | Diffusion Barrier For Use With High Dielectric Constant Materials And Electronic Devices Incorporating Same |
| 89100488 | | 2000-01-13 | | Abandoned | Taiwan | Diffusion Barrier For Use With High Dielectric Constant Materials And Electronic Devices Incorporating Same |
| 09478647 | 6340827 | 2000-01-06 | 2002-01-22 | Granted | United States of America | Diffusion Barrier For Use With High Dielectric Constant Materials And Electronic Devices Incorporating Same |
| | | | | | | Diffusion Barrier For Use With High Dielectric Constant Materials And |
| 60115783 | | 1999-01-13 | | Expired | United States of America | Electronic Devices Incorporating Same |
| 11356873 | | 1999-12-09 | | Abandoned | Japan | Deep Sub-Micron Metal Etch With In-Situ Hard Mask Etch |
| 1019990058177 | 716436 | 1999-12-16 | 2007-05-03 Granted | Granted | Korea, Republic of (KR) | Deep Sub-Micron Metal Etch With In-Situ Hard Mask Etch |
| 09212228 | 6194323 | 1998-12-16 | 2001-02-27 | Granted | United States of America | Deep Sub-Micron Metal Etch With In-Situ Hard Mask Etch |
| 953085370 | | 1995-11-28 | | Abandoned | France | Method Of Forming Metal Layers Formed As A Composite Of Sub-Layers Using TI Texture Control Layer |
| 953085370 | | 1995-11-28 | | Abandoned | Germany (Federal Republic of) | Method Of Forming Metal Layers Formed As A Composite Of Sub-Layers Using TI Texture Control Layer |
| 953085370 | | 1995-11-28 | | Abandoned | United Kingdom | Method Of Forming Metal Layers Formed As A Composite Of Sub-Layers Using TI Texture Control Layer |
| 953085370 | | 1995-11-28 | | Abandoned | Italy | Method Of Forming Metal Layers Formed As A Composite Of Sub-Layers Using TI Texture Control Layer |
| 7337694 | 3707627 | 1995-12-04 | 2005-08-12 Expired | Expired | Japan | Method Of Forming Metal Layers Formed As A Composite Of Sub-Layers Using TI Texture Control Layer |
| 9546636 | | 1995-12-05 | | Abandoned | Korea, Republic of (KR) | Method Of Forming Metal Layers Formed As A Composite Of Sub-Layers Using TI Texture Control Layer |

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| High Density Plasma Passivation Layer And Method Of Application | United States of America | Granted | 2000-11-28 | 1999-08-09 | 6153543 | 09370422 |
|---|-------------------------------|-----------|--------------------|-----------------------|------------|------------|
| Method Of Integrated Circuit Fabrication Including A Step Of Depositing Tungsten | United States of America | Expired | 1997-12-02 | 1996-05-14 | 5693561 | 08645852 |
| Low Temperature Deposition of Silicon Oxides for Device Fabrication | United States of America | Expired | 1997-07-01 | 1993-09-03 | 5643838 | 08116309 |
| Wire Bonding To Copper | Taiwan | Granted | 2001-03-21 Granted | 1999-11-24 | NI-129005 | 88120537 |
| Wire Bonding To Copper | Korea, Republic of (KR) | Granted | 2006-12-13 Granted | 2000-01-22 | 659801 | 2000003060 |
| Wire Bonding To Copper | Japan | Granted | 2004-07-16 Granted | 2000-01-17 | 3575676 | 2000007951 |
| Wire Bonding To Copper | United States of America | Abandoned | | 1999-01-23 | | 9236406 |
| Wire Bonding To Copper | France | Lapsed | 2008-08-13 Lapsed | 2000-01-13 | 1022776 | 3002086 |
| Wire Bonding To Copper | United Kingdom | Lapsed | 2008-08-13 Lapsed | 2000-01-13 | 1022776 | 3002086 |
| Wire Bonding To Copper | Germany (Federal Republic of) | Granted | 2008-08-13 Granted | 2000-01-13 | 60039800.5 | 3002086 |
| Wire Bonding To Copper | United States of America | Granted | 2002-10-29 | 2001-05-24 | 6472304 | 09864577 |
| Tungsten Formation Process | Korea, Republic of (KR) | Abandoned | | 1994-10-14 | | 9426313 |
| Tungsten Formation Process | United States of America | Abandoned | | 1993-10-22 | | 8141780 |
| Tungsten Formation Process | Italy | Abandoned | | 1994-10-12 | | 943074658 |
| Tungsten Formation Process | United Kingdom | Abandoned | | 1994-10-12 | | 943074658 |
| Tungsten Formation Process | Germany (Federal Republic of) | Abandoned | | 1994-10-12 | | 943074658 |
| Tungsten Formation Process | Japan | Abandoned | | 1994-10-24 | | 6255908 |
| Tungsten Formation Process | France | Abandoned | | 1994-10-12 | | 943074658 |
| Tungsten Formation Process | United States of America | Granted | 2001-11-27 | 1994-10-26 | 6323126 | 08329806 |
| Tungsten Formation Process | Japan | Abandoned | | 2008-05-12 | | 2008124287 |
| Six-to-one signal/power ratio bump and trace pattern for flip chip design | United States of America | Granted | 2003-07-08 | 2000-12-28 | 6591410 | 09752626 |
| Bonding pad for low k dielectric | United States of America | Granted | 2004-09-28 | 2003-06-20 | 6798035 | 10600255 |
| Novel barrier layer treatments for Tungsten plug | United States of America | Expired | 1997-02-04 | 1994-12-30 | 5599739 | 08366867 |
| Novel barrier layer treatments for Tungsten plug | Korea, Republic of (KR) | Abandoned | | 1995-12-29 | | 9565271 |
| Novel barrier layer treatments for Tungsten plug | Japan | Abandoned | | 1995-12-28 | | 3420751995 |
| Sub-Layers Using TI Texture Control Layer | United States of America | Expired | 1996-06-04 | 1994-12-05 1996-06-04 | 5523259 | 08349649 |
| Method Of Forming Metal Layers Formed As A Composite Of | | | | | | |
| Method Of Forming Metal Layers Formed As A Composite Of Sub-Layers Using TI Texture Control Layer | Singapore | Lapsed | 1997-12-19 | 1995-11-28 | 33616 | 95020178 |
| Title | Country | Status | GrantDate | FiledDate | PatentNo | AppNo |